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Desorption Mass Spectrometry

Are SIMS and FAB the Same?

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3M

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FOREWORD

The ACS SYMPOSIUM SERIES was founded in 1974 to provide a medium for publishing symposia quickly in book form. The format of the Series parallels that of the continuing ADVANCES IN CHEMISTRY SERIES except that, in order to save time, the papers are not typeset but are reproduced as they are submitted by the authors in camera-ready form. Papers are reviewed under the supervision of the Editors with the assistance of the Series Advisory Board and are selected to maintain the integrity of the symposia; however, verbatim reproductions of previously published papers are not accepted. Both reviews and reports of research are acceptable, because symposia may embrace both types of presentation.

PREFACE

MASS SPECTROMETRIC INSTRUMENTATION and the capabilities for analysis of organic and organometallic molecules have undergone revolutionary advances in the last 3 years. Perhaps the most notable advances are in the area of volatilization and ionization of samples. In 1981, a new ion source was developed for a conventional high-resolution magnetic mass spectrometer that allowed the chemist for the first time to analyze organic compounds that were ionic, nonvolatile, or thermally unstable. This ion source used a fast atom beam to generate the organic ions. Tremendous growth has occurred in the use of the fast atom bombardment (FAB) source in combination with conventional mass spectrometers, both in academic research and in industrial problem solving.

The technique of FAB mass spectrometry (FABMS) has many similarities to that of secondary ion mass spectrometry (SIMS). The basic designs of the ion sources are similar, and these sources may share a common mode of generating ions. However, many researchers using FABMS consider their work to be original discoveries and disregard a wealth of knowledge in the field of the surface scientist. The SIMS method is significantly ahead of FAB in its development. Those doing FABMS have much to learn from SIMS studies. This condition of two analytical techniques advancing down parallel paths without any interaction slows the progress in both fields and, more importantly, prevents full utilization of these techniques.

The symposium upon which this book is based was held to encourage an open dialogue between researchers in the fields of SIMS and FABMS. The intent of the symposium and this book is to provide the basis for an interdisciplinary discussion of both the theoretical and applied aspects of these surface analytical techniques. The goal is to demythologize the subject of particle bombardment and also to bridge the gap that often exists between researchers in the fields of SIMS and FABMS. Scientists with a modest knowledge of mass spectrometry should gain a clearer understanding of desorption techniques and how they can be applied.

The book is organized into three sections. The first contains the most recent views on fundamental aspects of particle bombardment. Discussions of ^{252}Cf plasma desorption and laser desorption mass spectrometry have been included for comparison. The second section addresses the issues involved in instrument design, covering work on liquid metal and FAB ion guns. The last part presents representative applications of these bombardment methods.

The historical development of particle bombardment was presented by R. E. Honig as a retrospective lecture at the 32nd Annual Conference on Mass Spectrometry and Allied Topics in San Antonio, Texas, in 1984. This excellent lecture has subsequently been published, and I recommend it for those who wish additional background on the topic [Honig, R. E. In *The 32nd Annual Conference on Mass Spectrometry and Allied Topics—Retrospective Lectures*; Finnigan, R., Ed.; American Society for Mass Spectrometry: East Lansing, MI, 1984; Honig, R. E. *Int. J. Mass Spectrom. Ion Phys.* **1985**, *66*, 31–54].

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Those serving with me on the organizing committee and contributing greatly to the success of the symposium were M. L. Gross, University of Nebraska; R. M. Hexter, University of Minnesota; and J. A. Leys and W. L. Stebbings, 3M.

I extend my sincere thanks to those who handled the many details associated with the symposium. Sharon Hunt handled preregistrations and mailed information to the conferees. Gary Korba organized the poster session and abstracts. On-site registration and other details were covered by Joe Schroepfer, Frank Dehn, Diane Schroepfer, and Deanna Stebbings.

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Molecular Secondary Ion Mass Spectrometry

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Progress in molecular secondary ion mass spectrometry (SIMS) is presented, with emphasis on applications and the mechanism of ion formation. The mechanism involves three processes: (1) energy conversion at the surface, (2) ion/molecule and electron transfer reactions in the selvedge, and (3) unimolecular dissociations of internally excited gas phase ions. The role of matrix effects in mechanistic studies is discussed, as are experiments which use chemical reactivity to gain insights into mechanism. The use of tandem mass spectrometry (MS/MS) in ion structural determinations in SIMS and other desorption ionization experiments is illustrated. MS/MS provides evidence for unimolecular dissociations of gas phase ions, which appear to underlie much of the fragmentation seen in molecular SIMS. Cases of strong molecule-surface interactions can result in dissociation in situ, however, and examples are collected. Applications of molecular SIMS in quantitative and trace analysis, chromatography, studies of ion chemistry, catalysis, and imaging are reviewed. Developing areas in molecular SIMS include highly endothermic fragmentations and ion beam induced surface reactions.

It is a remarkable feature of secondary ion mass spectrometry (SIMS) that considerable chemical information is accessible through the procedurally simple physical technique of sputtering. SIMS--especially under low primary ion flux conditions ("static SIMS," also known as "molecular SIMS" when applied to compounds)--provides information on molecular weight and molecular structure and allows isotopic analysis. The surface sensitivity of SIMS permits its use in imaging, in monitoring of surface

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reactions, and in characterizing the "local atomic structure" of the surface of a complex material. High primary ion fluxes are useful for depth profiling and for analysis of materials dissolved or suspended in liquid matrices. Some characteristics of molecular SIMS are given in Table I.

This review focuses on the phenomenon of molecular SIMS--that is, the physical and chemical bases for its many analytical applications. The applications themselves are also reviewed. The coverage is somewhat historical, emphasizing progress which has come out of this and other laboratories in the past five years. SIMS is discussed in the context of experiments using related desorption ionization (DI) methods, especially laser desorption (LD) and fast atom bombardment (FAB).

It will be helpful to start by considering the status of molecular SIMS as of 1980, with particular reference to a review (1) which summarized progress in molecular SIMS to that date. Perceptions of the basic mechanism in SIMS have changed surprisingly little in the ensuing period, although considerable advances have occurred in experimental and instrumental techniques. In 1980 fast atom bombardment mass spectrometry using liquid matrices did not exist, matrix effects in SIMS were little explored, and there were few SIMS studies of catalysts. Analysis of high molecular weight compounds by SIMS was hampered by the limitations of the quadrupole and low mass range sector analyzers which were used almost exclusively at that time.

While there has been rapid progress in each of these areas, the generation of polyatomic ions is still seen in the terms presented in 1980: (i) the conversion of energy from the form in which it is originally applied into net translational energy of a molecule sufficient to allow it to leave the surface, (ii) the ion/molecule and other chemical reactions which occur at the interface and in the selvedge and which transform the surface molecules of interest into gas phase ions suitable for mass analysis, and (iii) secondary processes which alter the nature of the ion beam after it leaves the interfacial region, especially fragmentation due to unimolecular dissociation of internally

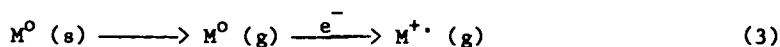
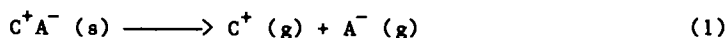
Table I. Some characteristics of molecular SIMS

Analyzer types	Quadrupole, sector(s), time-of-flight
Vacuum requirements	10^{-10} - 10^{-6} torr
Primary ion	Ar ⁺ , Xe ⁺ , Cs ⁺ , O ₂ ⁺ common
Primary ion current	< 1×10^{-8} A cm ⁻² for static SIMS, but higher currents sometimes acceptable
Primary ion energy	500-10000 eV common
Sample composition	Involatile organics, inorganics, and organometallics; semiconductors; adsorbed gases
Physical form of sample	Foils; bulk solids; compressed pellets; frozen and liquid matrices
Sample size	100 μ g - 10 ng common; bulk (multi-layer) samples often used
Sputtering yields	1% - 0.01% common
Secondary ion energy distribution	About 3 eV average, depending on sample; no high energy tail as with atomic species
Mass range	Usually below 2000 amu; > 20000 possible
Detection limit	$\leq 10^{-15}$ g for salts
Other features	Surface-sensitive; isotope-specific; can distinguish molecular weight, molecular structure; some capability for depth profiling and imaging

excited gas phase ions. The selvedge (the term is due to Rabalais (2)) is the plasma formed at and immediately above the surface during sputtering.

Figure 1 is an early representation of these three regimes with their distinctive physical and chemical phenomena (3). In this early picture, energy interconversion was considered as a form of isomerization--"energy isomerization"--leading to an expression of the excitation in a form more or less independent of the type of energy input. Vibrational excitation, especially of the lower frequency modes corresponding to intermolecular motion, was considered as the basis for desorption. Activation of surface phonons expresses these ideas in different currency.

Three types of ionization processes were distinguished (1) as contributing to the ions observed in molecular SIMS spectra: direct desorption of precharged materials, cationization/anionization, and electron ionization (Equations 1-3, respectively). The equations illustrate overall reactions and do not attempt to explain detailed mechanistic steps.



Desorption of precharged materials (i.e., salts) is a highly efficient process, since energy is not channeled into both an ionization step and a desorption step; previously existing ions are simply transferred from the solid phase to the gaseous phase. This effect may be seen in the ease with which SIMS spectra of quaternary ammonium salts are obtained (4). Derivatization of zwitterions to yield species with a net charge illustrates the same point. Cationization or anionization of neutral molecules by attachment of metal ions, protons, and other charged species is the second commonly observed ionization process in molecular SIMS (5). This may involve desorption of neutral molecules

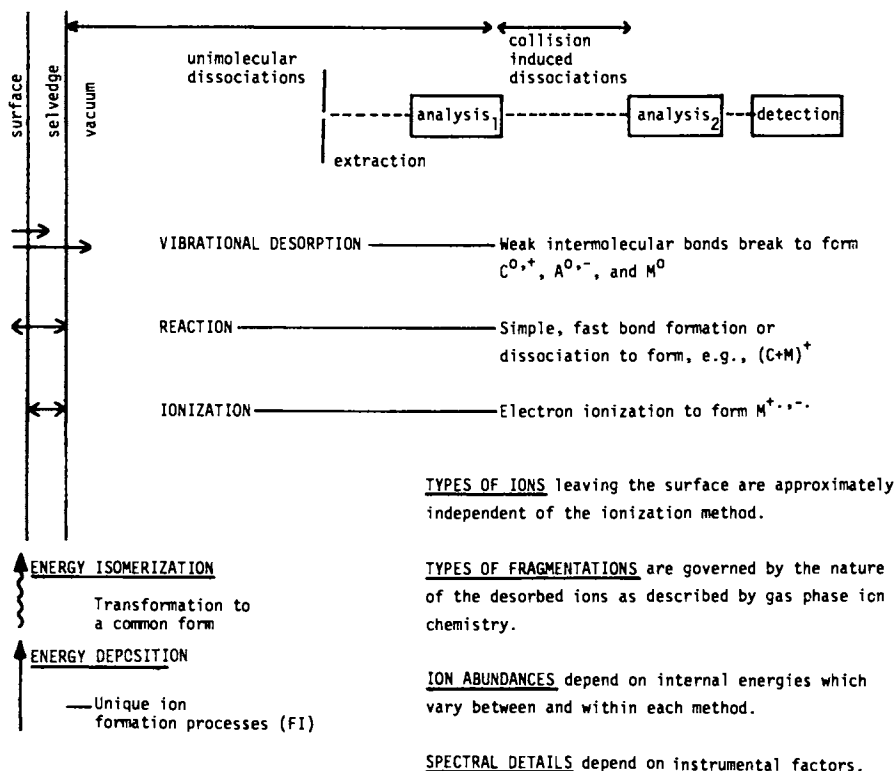


Figure 1. Early proposal of a unified model for SIMS and other desorption ionization experiments. Reproduced with permission from Ref. 3. Copyright 1983, Elsevier Science Publishers B.V. (First presented at a conference on ion formation from organic solids, Münster, West Germany, 1981.)

concurrently with metal ion production, followed by reaction in the selvedge to form an adduct. Electrons present in the selvedge as a result of secondary electron emission can ionize neutral molecules to give the third type of ionization process seen in molecular SIMS. This process, formation of cation and anion radicals, is not particularly efficient, but it can sometimes lead to abundant ions, for example, in SIMS spectra of polycyclic aromatic hydrocarbons (1).

In addition to those ions formed during or soon after primary ion impact, as in the processes just described, other ions arise through subsequent events. Unimolecular reactions of ions, akin to metastable decompositions in magnetic sector mass spectrometry, occur in the free vacuum. The resulting fragment ions have intensities which contradict the notion that SIMS is a "soft" ionization technique, although some fraction of the ion production events can be so characterized.

In the discussion of mechanism given below, support for the concepts just outlined will be marshalled from newer experimental results which are accommodated by the above model and which call for intact emission of molecules. It should be noted, however, that in the case of a strong molecule-substrate interaction, fragmentation probably occurs directly at the surface. Clearly this is the case when polymers are examined by bombardment techniques. Almost all molecular SIMS experiments employ static conditions in which virgin surface is selected for analysis. Typical maximum ion current densities of $1 \times 10^{-8} \text{ A cm}^{-2}$ correspond to ca. 6×10^{-5} ions s^{-1} per surface molecule of 10 \AA^2 area. This allows sputtering times to exceed one hour before there is a significant probability of examining modified surface material. However, examples are being encountered and will be discussed below where surface chemical reactions ("beam damage") do occur under static SIMS conditions in particular cases. This can produce extensive cleavages of high energy bonds and result in distinctive SIMS fragmentation behavior.

Data will also be given for other desorption ionization experiments which support the general notion of energy

isomerization, although no detailed treatment of energy interconversion is attempted. The third aspect of the SIMS mechanism, unimolecular dissociation of isolated gas phase ions, is also the topic of some of the newer experiments reported below, including those which utilize tandem mass spectrometry to characterize these events directly.

Mechanism

The fundamental nature of the desorption process is a continuing subject of controversy. The extensive literature on sputtering of atomic species has led to models which adequately explain most aspects of atomic SIMS (6, 7). Molecular SIMS, however, presents a greater challenge, and the means by which a large biomolecule becomes an ion are less clearly understood. Models have been proposed (8,9), and some current models of molecular desorption are described in the proceedings of this symposium (10-13). Our own qualitative but not untested views are given above and more extensively in the sections which follow. A significant question on which different views have been taken is this: Is fragmentation of stable, strongly internally bonded organic molecules upon primary ion impact significant, or is this overwhelmingly the result of delayed gas phase dissociations of energetic ions? There are dynamical calculations which confirm that such instantaneous dissociations can occur (14), and there are angle-resolved SIMS data which have been interpreted as evidence that they can be a major source of fragment ions (15). Much of the data for bulk samples presented and cited herein, including the similarities in behavior observed when comparisons are made with gas phase processes, lead to the opposite conclusion. Time-resolved experiments in the picosecond range might resolve this issue but are not now accessible.

A feel for the nature of the mechanistic problem can be had by examining the environment near the surface after an impact event using simple calculations and widely-accepted assumptions. It has been noted that a primary ion current density of $1 \times 10^{-8} \text{ A cm}^{-2}$

corresponds to 6×10^{-6} ions $\text{\AA}^{-2} \text{ s}^{-1}$. This means that, on the average, each area of $6 \times 10^6 \text{\AA}^2$ receives one "hit" by a primary particle each second. Because of the very large relative distances and long times between impacts, each must be considered as an isolated event. Consider that a single impact can sputter ten particles, each of mass 200 amu and kinetic energy 2 eV. Using the relation that kinetic energy = $1/2 mv^2$, where m is mass and v is velocity, the velocity of a 2 eV particle of mass 200 amu is $1.39 \times 10^5 \text{ cm s}^{-1}$, or $1.39 \times 10^{13} \text{\AA s}^{-1}$. The kinetic theory of gases makes possible the calculation of absolute pressure for particles of any kinetic energy through the relation $P = 1/3 nmv^2$, where n is the number of particles per unit volume (16). Since the mass of a 200 amu particle is $3.32 \times 10^{-22} \text{ g}$, the absolute pressure for ten such particles of 2 eV energy is $1.8 \times 10^{10} \text{\AA}^3 \text{ torr}$. If an appropriate volume can be justified, the pressure in this volume can be calculated by simple division. Suppose the selvedge region is a sphere of radius 50\AA ; half of the sphere is below the pre-impact level of the surface, and half is above it. The volume of this region is $5.2 \times 10^5 \text{\AA}^3$. The pressure in this volume is thus $3.5 \times 10^4 \text{ torr}$ as long as the ten particles remain within the sphere--a time of roughly $3.6 \times 10^{-12} \text{ s}$, assuming particles originate at the center of the sphere and there are no collisions.

It should be stressed that these calculations are of the most elementary nature and are meant only to give a feel for what the actual situation may be. If the chosen conditions are varied extensively, however, the basic conclusions remain unchanged. It is interesting to note that even within a volume of 10^{10}\AA^3 the pressure will still be about 1 torr. In this case particles will have existed for around 10^{-10} s (hundreds of bond vibrations). A recent FAB study (17) found evidence for sputtering from bulk glycerol, based in part on the sputtering of a 10^5\AA^3 volume with each primary particle impact (corresponding to ejection of more than 1000 glycerol molecules per Xe primary atom). Very high local pressures are clearly involved in FAB, a situation which supports the assumptions made in our own comparatively conservative

calculation. The picture of the selvedge that emerges is that of a very hot, high pressure region in which multiple collisions are possible. This can explain many of the experimental observations discussed below.

Matrix effects. While theoretical approaches to mechanistic studies form a large part of the literature, it is also possible to gain insight through observations based on chemical modification of the system of interest. Modification of the sample matrix provides one chemical approach to mechanistic information. Several different types of matrix effects have been observed. For example, Figure 2 shows SIMS spectra of mixtures of a quaternary ammonium salt and ammonium chloride. The neat compound gives an abundant intact cation at m/z 390, as expected for a precharged species. Rearrangement with loss of cyclohexene to give a fragment at m/z 308 is the dominant fragmentation process observed in the SIMS spectrum of this compound. Similar fragmentations, occurring via elimination of stable neutral molecules, are also observed when quaternary ammonium ions are collisionally activated (18). If NH_4Cl is physically mixed with the organic salt at dilutions of 1:2 and then 1:20, an increase occurs in the intact cation abundance relative to the fragment abundance (19). This effect occurs without a decrease in signal-to-noise ratio, even at dilutions as high as 1:1000. At such high dilutions the ratio of m/z 390 to m/z 308 levels off at a value of about 5:1. A tentative explanation for this matrix effect is that the intact cation is initially solvated by NH_4Cl . The NH_4Cl then forms NH_3 and HCl in a desolvation process which serves to take up internal energy from the cation. This loss of internal energy results in decreased fragmentation. The desorption/desolvation sequence suggested seems reasonable in view of observations (see below) of solvent-cation adducts in FAB (20), and of self clustering in FAB spectra of NH_4Cl itself (21) and SIMS spectra of low temperature matrices. An alternative explanation is that sputtered cations are collisionally relaxed by interaction with matrix species in the selvedge, a process only subtly different from

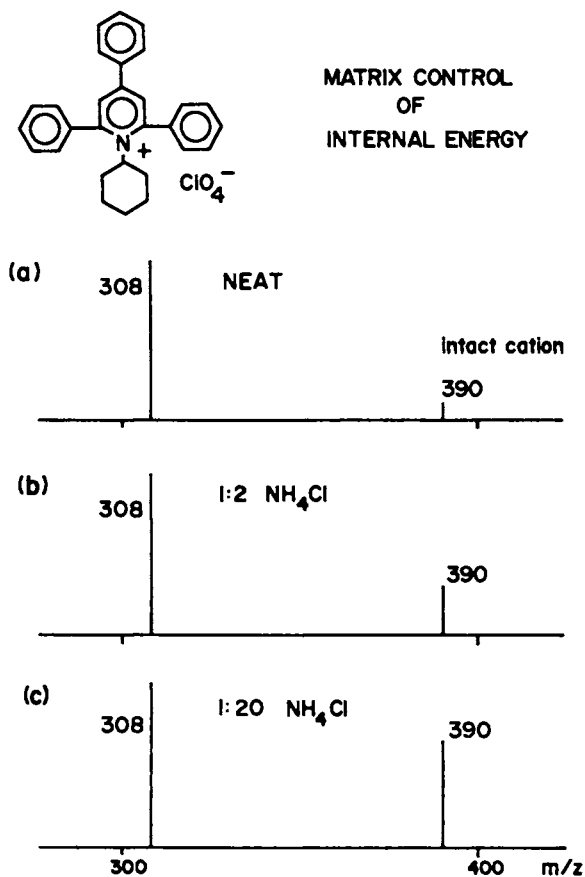


Figure 2. Effect of dilution in a matrix on fragmentation in SIMS. Reproduced with permission from Ref. 19. Copyright 1983, American Chemical Society.

desolvation. In either event, gas phase dissociations appear to occur subsequent to intact molecular emission.

A related matrix effect of considerable analytical interest is the enhancement in absolute ion yield sometimes observed under conditions of high dilution in a solid matrix (22). Comparison of the SIMS spectrum of a neat pyrilium salt with that of the same salt diluted 1000-fold in NH_4Cl shows that the intact cation signal is observed in about three times greater abundance for the NH_4Cl -diluted sample. The threefold increase is observed even when the absolute amount of salt analyzed in the dilute sample is one thousand times less than that in the neat sample. An additional aspect of this experiment is the persistence of the enhanced signal. Ion bombardment yields products for one day in the NH_4Cl matrix, but for only about one hour in the neat sample under identical conditions. Effective desorption of ammonium chloride, which entrains analyte, is one way of accounting for these observations.

Independently of the detailed model used to describe these matrix effects, one must propose that mixing on a molecular level occurs between the organic salt and the salt matrix in order to account for the dramatic observations. The effects are seen both for mixtures deposited on surfaces from solution and those burnished on as solids. Further evidence of mixing is provided by another effect of the matrix, the suppression of intermolecular reactions. Figure 3 shows SIMS spectra of carnitine hydrochloride as the neat material and when diluted 200 times with NH_4Cl . The neat compound undergoes intermolecular methylation to form the quaternary methyl ester, as evidenced by the presence of m/z 176 fourteen mass units above the intact cation at m/z 162. Addition of NH_4Cl causes a dramatic decrease in the abundance of the methylated cation, which indicates that neighboring group interactions are minimized in the presence of the matrix. The fact that this effect can be seen even for a physical mixture indicates that ion-beam-induced mixing must occur, either due to the agency of prior impact events or in conjunction with the desorbing impact itself. Impact of a single primary particle could cause mixing

over a much larger surface area than would be sampled in the concurrent sputtering event, so allowing mixing to occur under static SIMS conditions. Such mixing is consistent with observations by Michl (23) of cluster emission in SIMS of small molecule solids at cryogenic temperatures, and with the exchange of chlorine for hydrogen in physical mixtures of quaternary ammonium and metal chloride salts (24). Michl has advanced a cluster emission model which accounts for mixing in the hot ejected clusters and for subsequent cooling by ejection of small molecules. This is an attractive explanation of the effects we observe for room temperature salt matrices.

The mechanistic implications of another matrix effect currently under study (25) are not yet clear. This effect concerns the degree of fragmentation of anions as influenced by the nature of cations present in the matrix. Figure 4 illustrates negative ion SIMS spectra of potassium and ammonium perchhenate. A striking difference in the two spectra is the much greater abundance of ReO_3^- in the spectrum of NH_4ReO_4 vs. that of KReO_4 . If a physical mixture of NH_4ReO_4 and KCl is studied, the SIMS spectrum appears identical to that of KReO_4 . The suppression of fragmentation in NH_4ReO_4 is also effected by RbCl and CsCl , but not by NaCl or LiCl . This counterion effect may be associated with electron transfer phenomena in the selvedge.

While questions remain as to the origin of some matrix effects, manipulation of the matrix is being employed increasingly as a means for optimizing analyses. Chemistry plays a major role in processes occurring during sputtering. For example, Brønsted acid-base concepts have been used effectively to increase the abundances of certain ions in SIMS. Benninghoven (26) found that acidification of a solution from which glycine was deposited on a surface resulted in an increased abundance of $[\text{M}+\text{H}]^+$ ions, while addition of sodium hydroxide to the solution gave a maximum yield of $[\text{M}-\text{H}]^-$ ions. Addition of *p*-toluenesulfonic acid to sample matrices has been demonstrated to give enhancements in $[\text{M}+\text{H}]^+$ ion yields for a number of biological compounds in both SIMS and laser desorption (27). Recently this matrix enhancement strategy has

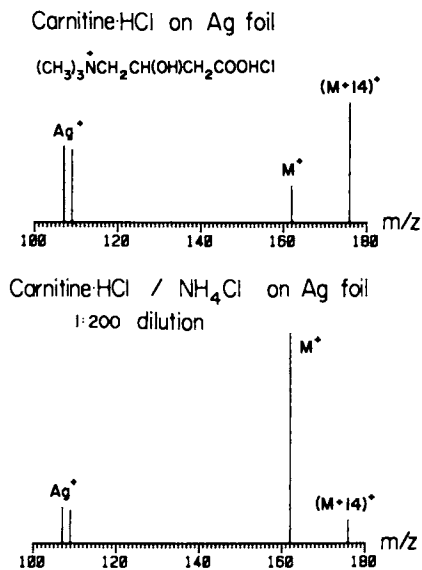


Figure 3. Decrease in abundance of the product of an intermolecular reaction (methylation to give 176^+) upon dilution in a matrix.

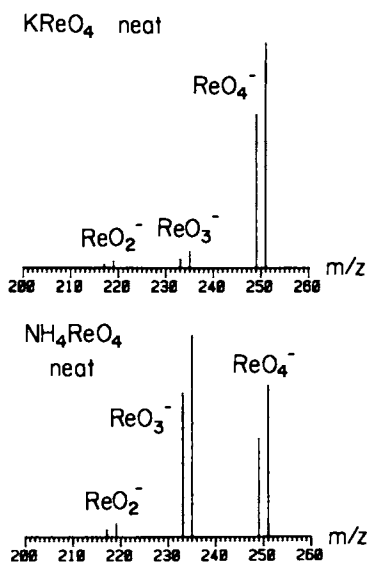


Figure 4. Effect of counterion upon fragmentation observed in SIMS.

been extended to the use of Lewis acids and bases. Todd, *et al.* (28) have achieved enhancements in M^+ ion yields in SIMS of pyrene dissolved in molten $SbCl_3$. The key here is the electron-accepting ability of $SbCl_3$, possibly resulting in formation of a charge transfer complex from which the pyrene molecular ion is easily desorbed.

Other experiments. While matrix effects can provide insight into the nature of the desorption process, there exist other more direct methods for obtaining information on the SIMS mechanism. Monitoring of secondary ion intensity *vs.* secondary ion or primary ion kinetic energy can sometimes provide mechanistic information (see, for example, Rabalais, *et al.* (29)). Primary ion currents can be varied, and beam damage at high fluxes may be indicative of particular processes (see below). Also of use is variation of the nature of the primary ion itself. For example, sputtering of metals or semiconductors with O_2^+ produces enhancement in ion yields in comparison to inert gases such as Ar^+ ; this can be explained as the result of oxidation of the material, forming a band gap which limits neutralization of sputtered ions on emission (30). (Oxidation also allows direct desorption of precharged ions.) Variation of the azimuthal angle of incidence of primary ions and measurement of the angular distributions of secondary ions have been used by Winograd (31), often in conjunction with classical dynamics calculations (32), to study cluster formation and surface configurations of adsorbed species.

The time dependence of desorption remains a little-explored but potentially useful approach for mechanistic studies. Cotter (33) has monitored secondary ion kinetic energies in a laser desorption (LD) time-of-flight instrument. Laser pulses 40 ns wide were used to desorb K^+ ions from solid KCl, and the ions were sampled at variable times after the laser pulse. Emission persists for several microseconds after excitation, and secondary ion kinetic energies were found to decrease when examined at longer times after excitation. This result supports a thermal model for

LD in which relaxation occurs after an initial high temperature spike. Time-of-flight instruments are well suited for such time-dependent studies, since the time variable is measured directly. In addition to its use in LD, TOF is used exclusively in plasma desorption (PD) (34) and is being used increasingly in SIMS (35,36). It is noteworthy that a time resolution of about 10^{-11} s in field ionization is the present limit attainable in any technique (37). If the desorption process itself occurs on the order of one vibrational period (10^{-13} s) (38), any information to be gained about the very early stages of desorption is at present not obtainable through measurement of time delays. Such small delays are of prime interest, however, since processes occurring through selvedge reactions could then be distinguished from direct emission processes, direct emission could in turn be distinguished from unimolecular fragmentation, and information could be gained on the nature of energy randomization at the surface.

There may also be mechanistic information available in TOF peak shapes. Figure 5 compares types of peaks encountered in three different analyzers if a repelling voltage V (39) is applied after full acceleration from the ion source, but prior to detection (TOF) or mass analysis (quadrupole and magnetic sector). For TOF and magnetic analyzers, broad metastable peaks are indicative of decomposition after full acceleration. Since the quadrupole analyzes mass directly, there is no metastable peak in the unmodified analyzer, regardless of the value of V . In the case of magnetic sector analysis, a metastable peak appears as long as V is held below a critical value V_c , where V_c equals the kinetic energy partitioned into the fragment ion. (This discussion neglects fragmentation in the region following application of V_c ; this would give rise to a second peak.) When V surpasses V_c , the metastable peak is no longer observed, while the narrow peak due to ions with full accelerating voltage remains. If V is zero in the TOF case, the peak shows a pronounced broadening at the base. Application of a repelling voltage allows separation of this broad peak into two components: that due to stable and that due to

metastable ions. Increasing V to V_c and beyond results in complete repulsion of the metastable component, with a slight lengthening of the flight time for stable ions as a result of the repelling voltage. Determination of the threshold energy for metastable decomposition gives information on the internal energies of secondary ions, which ultimately leads back to the desorption process. Determination of internal energy distributions in sputtered ions seems feasible using new methods (40), and this should provide further mechanistic insights.

A time-of-flight instrument (41) has recently been constructed for the purpose of observing metastable decompositions of ions formed in plasma desorption. The instrument uses an electrostatic mirror to reflect the ion beam while permitting neutrals to pass through unhindered to a detector. One operating mode involves acquisition of a spectrum with the electrostatic mirror disabled, allowing both ions and neutrals to strike the detector behind the mirror. A second measurement with the mirror operating will give a spectrum of neutrals only. These neutrals must have been formed by in-flight decomposition of ions, since neutrals could not be accelerated out of the instrument source. The neutrals, having the same velocities as the parent ions from which they arise, appear at flight times identical to those of the unfragmented parent ions. The integrated peak ratio (neutrals)/(neutrals + ions) gives a direct measure of the contribution of metastables to a TOF peak. In some cases, 80% to 90% of the peak area comes from metastable decompositions (42). A second operating mode of this instrument is a coincidence experiment in which detection of both neutrals and reflected ions is accomplished simultaneously. It is possible in this mode to identify fragment ions formed by dissociation of a particular parent ion—a capability of great importance for ion structural and mechanistic studies.

There are a number of recent studies which, though not aimed specifically at determining the mechanism of desorption, point the way to future experiments in this area. FAB of quinone antibiotics (43) appears to be accompanied by reduction. Quinones with low

reduction potentials give large $([M+2H]^+ + [M+3H]^+)/[M+H]^+$ and $([M+H]^- + M^{\cdot-})/[M-H]^-$ ratios. The ratios follow polarographically-measured potentials and are dependent on solvent, analysis time, and quinone structure. A FAB study by Bursey, *et al.* (44) has quantitated the competition for alkali metal cations between solvent glycerol and solute phthalic acid. A fuller understanding of this competition and of the processes involved in the reductions could aid greatly in the explanation of matrix effects. The information now available points to significant contributions of both selvedge ion/molecule reactions and subsequent unimolecular dissociations. Using tandem mass spectrometry (see below), Keough (45) has found strong evidence for desolvation processes in FAB spectra of sucrose and glucose in NaCl-doped glycerol. Solvated clusters generated in FAB were collisionally dissociated and found to yield fragments of the same composition as other ions in the FAB survey spectrum. It is reasonable to suppose that many ions in FAB and SIMS result from similar unimolecular dissociations.

Control of target surface potential has been used to increase the specificity of the information available from SIMS. Detection of inorganic constituents in coal and polymer samples (46) is hampered by the strong molecular ion backgrounds often present. By charging a surface to a particular value, secondary organic ions with low kinetic energies can be suppressed, while the higher energy atomic ions are transmitted. This method is a variant on secondary ion kinetic energy analysis.

An experiment related to that above involves heating or cooling surfaces to observe the effects, if any, on sputtering. A SIMS study of ethylene adsorbed on ruthenium (47) suggests the type of information obtainable with surface temperature variation. In Figure 6, ions produced by sputtering were monitored during application of a temperature ramp to a Ru(001) surface. While all the catalytic implications of this data will not be discussed, the figure is informative in a mechanistic sense. For example, the fact that RuC^+ and RuC_2^+ increase as Ru^+ increases indicates a local surface RuC_2 unit or recombination of neutral C

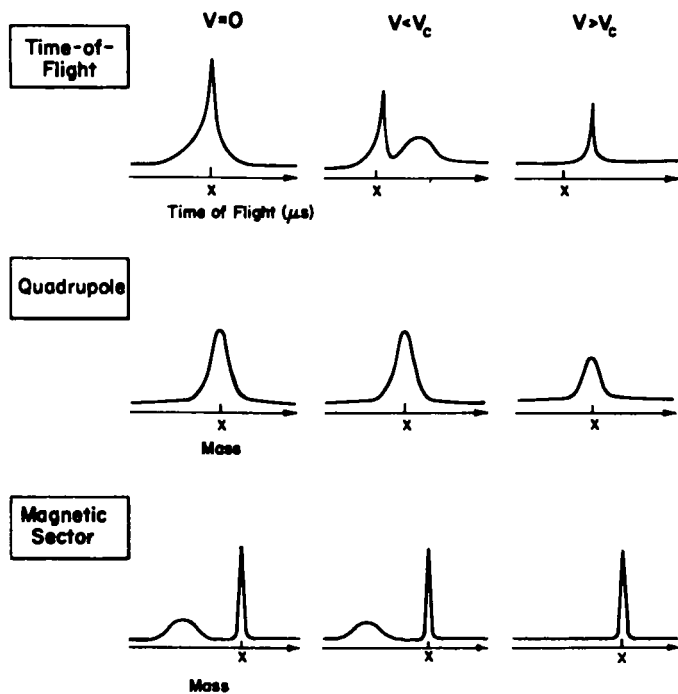


Figure 5. Effect of gas phase fragmentation upon peak shapes observed using different mass analyzers for SIMS.

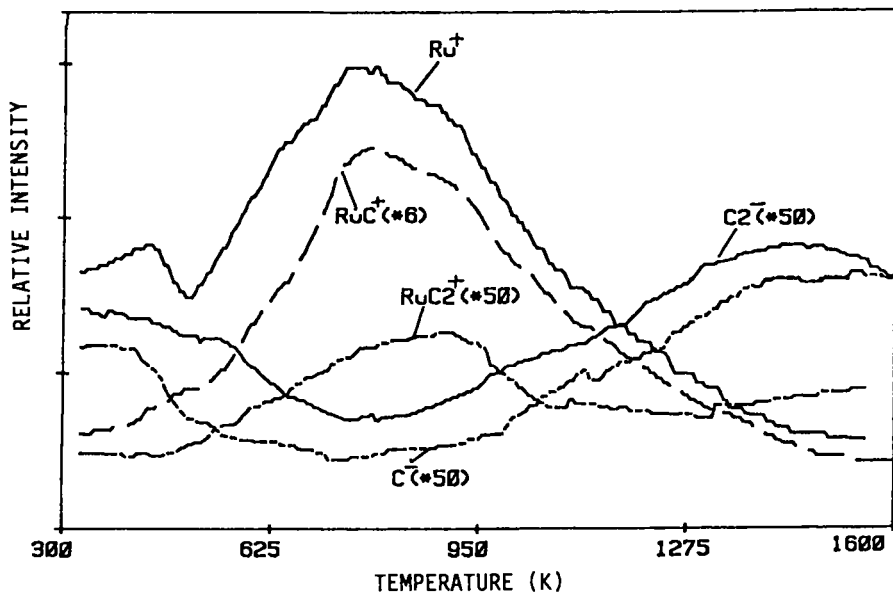


Figure 6. Surface temperature dependence of the SIMS spectrum of ethylene on Ru.

or C_2 species with Ru^+ in the selvedge. The fact that no positive C^+ or C_2^+ ions could be observed rules out participation by neutral Ru in the cationization process.

Alternative methods of energy deposition. The relationship between SIMS and other desorption ionization techniques can provide additional mechanistic insights. In laser desorption, as in SIMS, the processes of cationization/anionization, direct desorption of precharged materials, and electron ionization (Equations 1-3) are easily recognized. The similarities between the two methods can be illustrated by comparing studies of doubly-charged organic salts (such as diquatery ammonium salts) (33,48). These compounds fail to show doubly-charged ions in LD, although abundant $[M-H]^+$ or $[M-CH_3]^+$ ions are seen along with singly-charged fragments. Dissociation of diquatery ammonium salts into two singly-charged quaternary ions is sometimes observed, as is substitution of halogens for hydrogen. In rare instances, doubly-charged ions can be observed in SIMS (49). The similarities between SIMS and LD spectra, especially those obtained with pulsed beams, far outweigh the differences, and this is significant in view of the completely different means used for excitation.

The techniques of field desorption (FD) and electrohydrodynamic ionization (EHD) differ from SIMS, LD, and FAB in their physical basis and in features seen in the spectra. For example, the diquatery ammonium salts discussed above yield intact doubly-charged ions, and fragmentation is less extensive. Nonetheless, the three classes of ions described for molecular SIMS are generally seen in FD (50). An EHD study of a series of diquatery ammonium salts (51) led to the conclusion that the amount of internal energy deposited in EHD is less than in SIMS and FAB. The same study also indicated that FAB (liquid matrix) deposits less energy than SIMS (solid matrix), so in this case the order of energy deposition is SIMS > FAB > EHD.

It is generally recognized that FAB and SIMS really represent one and the same sputtering phenomenon. The charge borne by the

primary particle is of little mechanistic consequence, and it is the liquid matrix which is responsible for the advantages and disadvantages of FAB. A direct comparison between spectra obtained with Cs^+ and Xe^0 primary beams has been reported (52). Peptides, lipids, nucleotides, and steroids desorbed from glycerol are found to exhibit virtually identical spectra with both Cs^+ and Xe^0 primary particle bombardment. The only significant difference is an increase in secondary ion intensity with Cs^+ , probably due to the ability to better focus the charged beam.

In contrast to SIMS and FAB, plasma desorption employs heavy, very high energy (MeV) fission fragments as primary particles. The flux of these particles is much lower than fluxes used in SIMS and FAB. The primary excitation process in PD is electronic, while that in SIMS and FAB is generally considered to arise from nuclear stopping (53). Due to this electronic excitation there is a dependence on the charge state of the primary particle, unlike the situation in SIMS and FAB. Despite differences in the early stages of ionization, however, the same types of ions seen in SIMS, FAB, LD, and FD are also seen in PD. This suggests conversion of energy to a common form after the initial energization process.

Summary of mechanism. Taking into account the data in hand (and that which follows), it is possible to classify the many processes which occur in molecular SIMS in a qualitative manner. Table II, while not complete, illustrates many of the processes which contribute to molecular SIMS, FAB, and LD spectra. The following synopsis of the mechanism complements the material in Table II:

(1) Upon particle impact, energy is deposited into a surface and distributed through momentum transfer and vibrational and rotational excitation. This leads to heating, electron and photon emission, neutral particle emission, and ion emission.

(2) There are, initially, at least three types of molecular ions from which other ions may be derived. These are formed by electron ionization, direct desorption, and ion/molecule processes, especially cationization/anionization. The means by which these

Table II. Ion formation processes in molecular SIMS

Reaction	Probable region of occurrence	Comments
$M^0(s) \longrightarrow M^0(g) \xrightarrow{+e^-} M^+(g)$	selvedge	electron ionization
$C^+(s) \longrightarrow C^+(g)$	surface	direct desorption
$M^0(s) \longrightarrow M^0(g) \xrightarrow{+C^+} (M+C)^+(g)$	selvedge	cationization
$M^0(s) \longrightarrow M^0(g) \xrightarrow{+A^-} (M+A)^-(g)$	selvedge	anionization
$M^0(s) \longrightarrow M^0(g) \xrightarrow{+H^+} (M+H)^+(g)$	selvedge	cationization by protonation
$(C_m A_n)^{\pm}(s) \longrightarrow (C_m A_n)^{\pm}(g)$	surface	direct cluster desorption
$C^+(s) + nS^0(l) \longrightarrow CS_n^+(g)$	surface (liquid)	solvent attachment
$C^+(g) + nS^0(g) \longrightarrow CS_n^+(g)$	selvedge	cationization of solvent
$CS_n^+(g) \longrightarrow C^+(g) + nS^0(g)$	free vacuum	desolvation
$M_1^0(s) + M_2^0(s, l) \xrightarrow{\pm e^-} M_1^{\pm}(g) + M_2^{\pm}(s, l)$	selvedge	electron transfer
$M^0(s) \longrightarrow F(g) \xrightarrow{+C_n^{\pm}(g)} (C_n + F)^{\pm}(g)$	surface \rightarrow selvedge	"beam damage"
$[C^0(s) + Ad(g)] \longrightarrow (C + Ad)^{\pm}(g)$	surface	intact emission
$Ad(g) \xrightarrow{+C^+} (C + Ad)^+(g)$	selvedge	cationization
$nC(s) \longrightarrow C_n^{\pm}(g)$	surface	intact cluster emission
$M_1^0(s) + M_1^0(s) \xrightarrow{+H^+} (2M_1 + H)^+(g) \longrightarrow M_2^+(g)$	surface	surface reaction
$\curvearrowright F$	free vacuum	unimolecular fragmentation

M = molecule, C⁺ = cation, A⁻ = anion, C = atom or molecule, S = solvent, Ad = adsorbed species, F = fragment, m, n = positive integers

ions arise are to some degree obscure. For example, electron ionization may involve direct selvedge ionization of neutrals, but it could also involve charge exchange or electron loss concurrently with the actual desorption of a molecule.

(3) Ions formed in the selvedge can react with other ions or neutrals to form clusters and other secondary products. Ions sputtered from liquid matrices can cationize solvent molecules.

(4) Some clusters may be desorbed as intact units. Likewise, solvated adducts may be desorbed from liquid matrices directly.

(5) Under normal experimental conditions, unimolecular fragmentation and desolvation occur predominantly in free vacuum above the selvedge.

(6) Especially under high flux conditions, some molecules can be fragmented directly at the surface, and these fragments can form adducts in the selvedge.

Although they specifically describe the behavior of organic molecules, it is interesting to examine the extent to which the preceding generalizations apply to simple metal salts (54). Figure 7 is a portion of the FAB spectrum of SbCl_3 . A distinguishing feature of this spectrum is the presence of successive losses of neutral HCl from ions solvated by glycerol. The negative FAB spectrum of SnCl_4 contains similar HCl losses and a series of SnCl_x^- peaks arising from addition of Cl^- to SnCl_4 (presumably in the selvedge) and apparently from successive losses of Cl_2 (free gas phase). In these cases, heterolysis of the substrate (e.g., to give SnCl_5^- and SnCl_3^+) followed by solvation in the selvedge and unimolecular fragmentation via elimination of stable neutral molecules accounts for much of the behavior observed in FAB.

Tandem Mass Spectrometry (MS/MS)

An additional dimension of information can be added to desorption techniques if a second stage of mass analysis is used. Typically an ion is mass-selected with a quadrupole or magnetic sector and allowed to pass into a collision cell. A target gas in the

collision cell causes collisional activation of the ion, which then fragments. Fragment ions are mass-analyzed to obtain a daughter spectrum. An alternative scan mode--the parent scan--involves setting the second analyzer to select ions of a constant mass while the first analyzer is scanned; this produces a spectrum of ions which fragment to give a particular daughter ion. MS/MS is very useful in ion structure determinations, especially in cases where an abundant molecular ion and an absence of fragment ions are encountered. It also has proven valuable in providing evidence that gas phase dissociations are responsible for the fragment ions observed in SIMS and FAB spectra of (i) thiamine, (ii) NH_4Cl , and (iii) silver propionate, to give a few particular examples which will be considered in turn.

MS/MS daughter spectra of a number of ions generated by sputtering of organic materials in liquid and solid matrices have been reported (55). In one experiment the intact cation (m/z 265) of thiamine HCl was selected and found to fragment by cleavage into two main fragments (m/z 122 and m/z 144). This reaction is identical to that seen in the SIMS survey mass spectrum of thiamine HCl itself. An ion at m/z 357 was observed in the SIMS spectrum of thiamine HCl from glycerol; this is the adduct $[\text{M}+\text{G}]^+$, where M is the intact cation and G is glycerol. The daughter spectrum of this ion was expected to show simple loss of glycerol accompanied by thiamine fragments. This indeed occurs, but the base peak in the daughter spectrum is m/z 238, which formally corresponds to loss of glycerol and an additional 27 mass units (probably HCN). Apparently the glycerol solvent reacts with the thiamine cation to form new covalent bonds. This is an example of an intimate solvent-analyte association (as contrasted with solid matrix data in which very loose associations are normally indicated).

In the same study, an unexpected result was observed in the daughter spectrum of the intact cation (m/z 162) from carnitine (see Matrix effects, above). The base peak in SIMS MS/MS is m/z 103, corresponding to loss of trimethylamine by rearrangement, while the same ion in the SIMS survey spectrum is nearly absent. This is a striking case of different behavior between SIMS and gas

phase fragmentations. Its origins are not entirely clear, although dissociation in SIMS is influenced by the nature of the matrix, pointing to the occurrence of fragmentation in the selvedge.

A study of silver carboxylates (56) employing evaporation followed by electron ionization (EI) in conjunction with MS/MS allowed structures to be formulated for certain ions observed in SIMS. The SIMS spectrum of silver propionate, for example, contains unusual ions indicative of high energy bond cleavages, in contrast to most other molecular SIMS spectra. These ions are AgCO^+ , AgCO_2^+ , Ag_2O^+ , and especially $\text{Ag}_2\text{C}_2\text{H}_5^+$ and $\text{Ag}_2\text{propCH}_2^+$ (prop = $\text{CO}_2\text{C}_2\text{H}_5$). In addition, Ag^+ , Ag_2^+ , Ag_3^+ , Ag_2H^+ , Agprop^+ , and Ag_2prop^+ were observed. Ideally the structures of some of these ions would be determined with SIMS MS/MS. When this direct method was not available, EI spectra from a vaporized sample were acquired on a triple quadrupole mass spectrometer. The ions observed in EI were the same as in SIMS, with the exception of Ag_3^+ (absent) and Ag_2CO^+ and Ag_2CO_2^+ (very weak). The similarity between the spectra may be indicative of both (i) thermal processes occurring in SIMS and (ii) unimolecular dissociations occurring in the free vacuum region. Parent and daughter MS/MS scans produced the data in Scheme 1, which shows the origins and fates of the various Ag_2 -containing species. Ag_2prop^+ is seen to be a parent of Ag_2CO^+ and Ag_2CO_2^+ , which arise by cleavage of C-C bonds in the metal-containing cluster ion. Formation of these ions in SIMS is therefore reasonably ascribed to gas phase dissociations. Particularly interesting is the Ag_2H^+ ion, which does not fragment to Ag_2^+ , in contrast to ions like Ag_2CO^+ and Ag_2prop^+ , which do. The conclusion is that Ag_2CO^+ contains a Ag-Ag bond, while Ag_2H^+ has a proton-bound Ag-H⁺-Ag structure. In cases like this, MS/MS can offer important insights into molecular structure otherwise unobtainable with only one stage of mass analysis.

The observation of high mass clusters is familiar in SIMS, and so it is not surprising that NH_4Cl clusters are observed in FAB (21). Like the solid alkali halides (57), NH_4Cl produces a

series of clusters containing gaps at certain masses. Figure 8 is a portion of the positive ion FAB spectrum of NH_4Cl . Clusters are clearly evident by the distinctive chlorine isotope patterns and are described by the formula $[(\text{NH}_4)_x\text{Cl}_{x-1}]^+$. Clusters in SIMS, too, commonly have this general $[\text{C}_x\text{A}_{x-1}]^+$ formula (30). In this particular case, clusters were observed from $x = 1$ to $x = 38$. At increasingly high masses, ion intensities decrease, with exceptions at $x = 38, 32, 23,$ and 14 , where intensities are notably greater than expected. Gaps occur in the cluster series at $x = 31, 24, 22,$ and 15 . The gap for $x = 15$ ($[(\text{NH}_4)_{15}\text{Cl}_{14}]^+$) is clearly evident in Figure 8. To study the absence of an $x = 15$ ion further, daughter spectra of the $x = 17$ (m/z 872) and $x = 16$ (m/z 819) ions were recorded. The $x = 17$ ion was found to fragment to $x = 16, 14, 13, \dots$, with $x = 15$ being absent. The $x = 16$ ion was found to lose two NH_4Cl groups to give the series $x = 14, 13, 12, \dots$. Thus, the $x = 15$ cluster was not observed in any of the experiments and is clearly of low stability. The MS/MS data confirm that the key elements of the desorption ionization spectra arise as a result of unimolecular fragmentations, as shown earlier for cesium iodide by Standing and coworkers (58).

Applications

Quantitative and trace analysis. Quantitative analysis by SIMS must be performed with an awareness that different materials have different sputtering yields, and thus a large peak for one material may or may not indicate that it is present in greater abundance than a material which gives a smaller peak. If appropriate standards are used, however, it is possible to accurately quantitate materials in SIMS. As one example, full spectra of good quality and signal persistence of at least thirty minutes under static SIMS conditions have been reported for therapeutic quaternary pyridine aldoximes at the 50 ng level (59). Monitoring of only one ion and/or signal averaging could be used to lower the detection limit substantially.

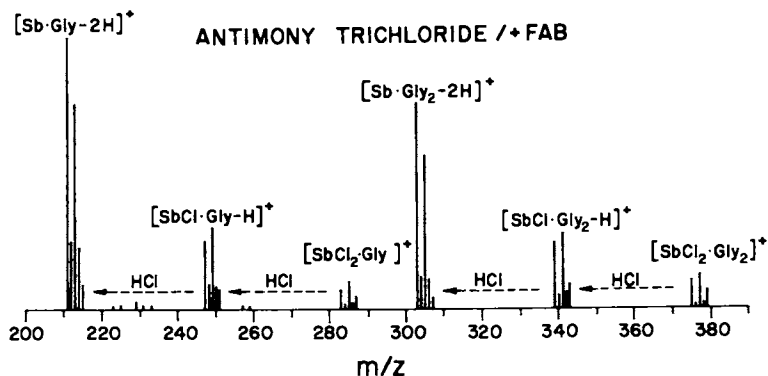
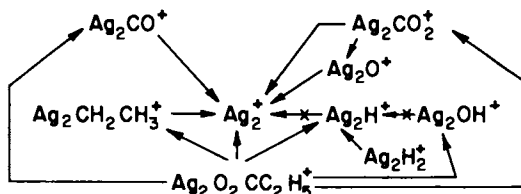


Figure 7. FAB spectrum of SbCl_3 in glycerol showing fragmentations leading to lower mass ions.



Scheme 1. Ion relationships in silver propionate determined by Ms/Ms. Reproduced with permission from Ref. 56. Copyright 1984, American Chemical Society.

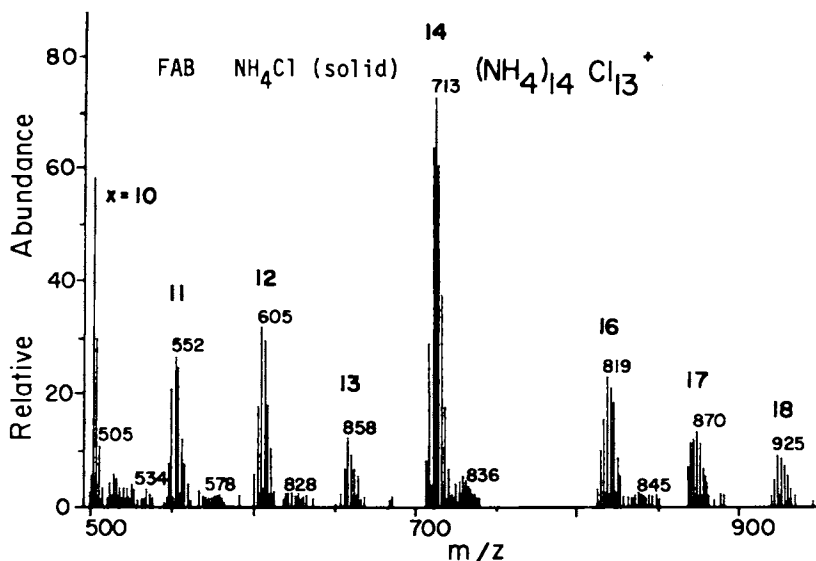


Figure 8. FAB spectrum of solid NH_4Cl showing gap in cluster ions at $(\text{NH}_4)_{15}\text{Cl}_{14}^+$.

As in many other quantitative mass spectrometric studies, the best quantitative results are often obtained in molecular SIMS through use of isotopically-labelled internal standards. This procedure has been successfully used in quantitating the extent of methylation of nucleosides produced by *in vitro* methylation of DNA (60). Figure 9A is the SIMS spectrum of 3-methylcytidine (m^3C), characterized by the 3-methylcytosine ion (arising from cleavage of the ribose sugar) at m/z 126. Methylated polycytidylic acid, enzymatically degraded in the presence of deuterated 3-methylcytidine ($[methyl-^2H_3]m^3C$), gives the SIMS spectrum in Figure 9B. The ion at m/z 112 is protonated cytosine. The deuterated standard shows a peak at m/z 129 which can be compared to the m/z 126 peak arising from m^3C produced by degradation. In this case, 22% of m^3C was found in the methylated polycytidylic acid, a figure which agrees with that obtained in studies by high performance liquid chromatography and nuclear magnetic resonance.

An important tool for quantitative as well as qualitative analysis by molecular SIMS is reverse derivatization (27). In contrast to derivatization normally encountered in mass spectrometry, in which an involatile material is made more volatile, derivatization reactions appropriate to DI yield a salt which can be efficiently ionized. Figure 10 demonstrates one such derivatization reaction (61) in which corticosterone reacts with Girard's reagent P to form a pyridinium salt. Positive ion FAB analysis of the derivatized material produces an abundant intact cation for as little as $1 \mu g$ of sample ketosteroid.

Trace analysis by SIMS can achieve strikingly low detection limits, even for impure samples and mixtures, when care is taken to optimize each aspect of the experiment. Benninghoven's work on biomolecules in the 1000-2000 molecular weight range (62) demonstrates this point, with 10^{-15} mol detection limits being available in a TOF analyzer. The important factor in this work is the use of a sputter-cleaned noble metal substrate, which allows deposition from solution of monolayers or submonolayers of sample. The use of chemical ionization with MS/MS has enabled detection of

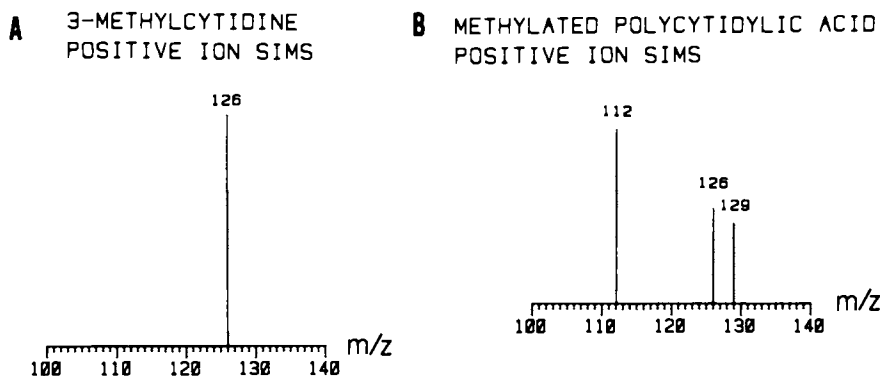


Figure 9. (A) Partial SIMS spectrum of 3-methylcytidine, with the 3-methylcytosine ion at m/z 126. (B) Quantitation of 3-methylcytosine (m/z 126) by SIMS using a d_3 -labeled internal standard (m/z 129).

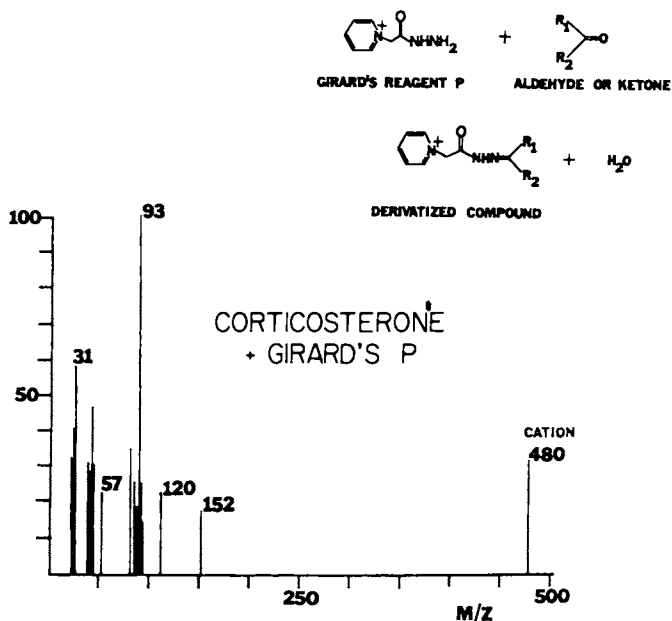


Figure 10. Derivatization in SIMS used to obtain efficient ionization of nonpolar compounds.

picogram amounts of components in biological mixtures (63), and SIMS may provide even lower detection limits for mixture analysis.

Chromatography. SIMS is particularly well-suited to the analysis of materials separated by paper chromatography, thin layer chromatography (TLC), and electrophoresis. Since sample is already present on a solid support in these methods, direct analysis of separated components is easily performed. Detection of the quaternary ammonium salt muscarine in a mushroom extract (64) exemplifies the technique. Detection limits are about 10 μg for in situ analysis of TLC spots, but by scraping off spots and redepositing them on metal supports, limits two to three orders of magnitude better are obtained. This is due to removal of much of the background signal which arises from the plate and to sampling of more material (SIMS samples only surface material, so material absorbed into the silica gel or cellulose layers will not be sampled). SIMS has also been used as a detector for liquid chromatography (65), but this is experimentally more difficult than detection of TLC spots.

Ion Chemistry. Quite often in molecular SIMS, fragmentation is observed which can be explained through simple schemes of the sort commonly encountered in electron impact and chemical ionization mass spectrometry. Consider Figure 11, the SIMS spectrum of nicotinamide (18). A number of peaks are apparent, and Scheme 2 serves to explain many of them. After argentation at the ring nitrogen atom, an additional silver atom may replace a hydrogen to give the $[2\text{Ag}+\text{M}-\text{H}]^+$ ion, followed by loss of HNCO to give $[2\text{Ag}+\text{M}-\text{H}-\text{HNCO}]^+$. (The attachment of Ag_2 to $[\text{M}-\text{H}]^+$ is apparently precluded here, since no $[\text{M}-\text{H}]^+$ fragment ion is seen.) Attachment of two silver atoms is probably a selvedge process, while loss of HNCO is a free gas phase fragmentation, as indicated by direct experiments with the corresponding protonated compound. Other peaks in the spectrum are easily recognizable: the radical nicotinamide cation M^{\bullet} , the protonated nicotinamide cation $[\text{M}+\text{H}]^+$, the silver cluster Ag_3^+ , and a Ag_2Cl^+ impurity cluster with the familiar $[\text{C}_x\text{A}_{x-1}]^+$ composition.

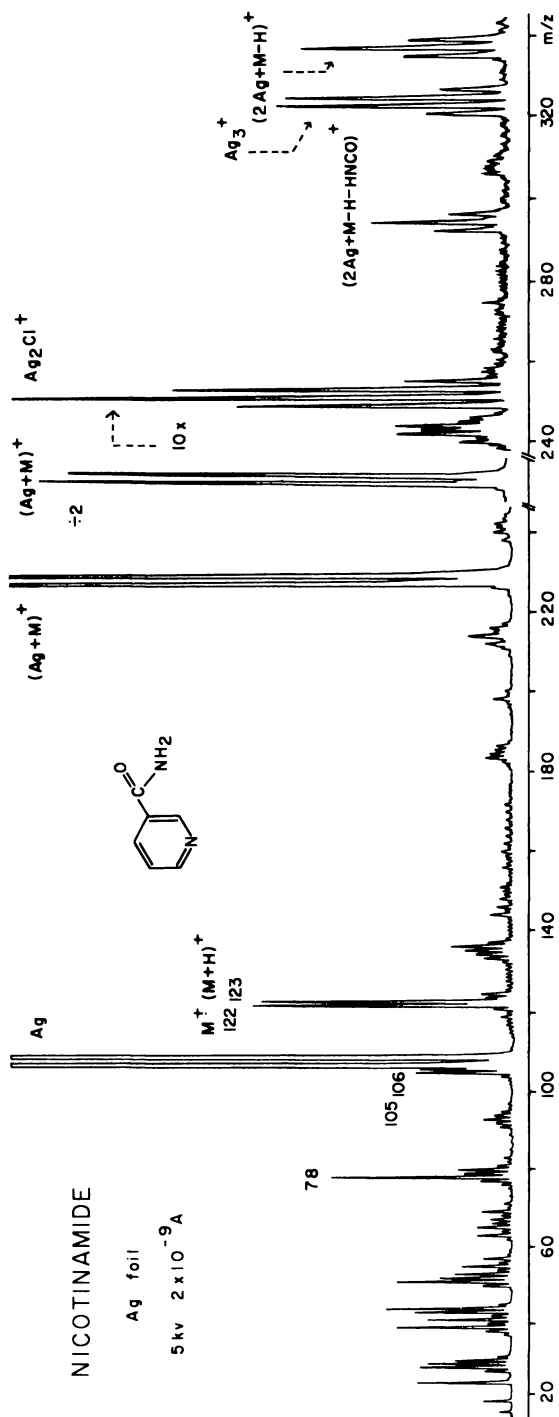


Figure 11. SIMS spectrum of nicotinamide. Reproduced with permission from Ref. 18. Copyright 1981, Elsevier Science Publishers B.V.

Interesting behavior has been observed in SIMS of some mixtures of tetrahedral inorganic complexes (66). Table III presents ions observed in the SIMS spectrum of a 1:1 mixture of copper methyl and silver cyclohexyl isocyanides. A graphite support and granulated graphite matrix were found to give the best signal/noise ratios. Considerable mixing in the selvedge is suggested by ligand exchange (e.g., $[\text{Cu}(\text{CNCy})_2]^+$ and $[\text{Ag}(\text{CNCH}_3)_2]^+$) and by the presence of mixed ligand species ($[\text{Cu}(\text{CNCH}_3)(\text{CNCy})]^+$). On the basis of a growing number of studies of inorganic compounds and coordination complexes (67-69) it is apparent that intermolecular reactions are far more likely for these compounds than for organic compounds. One surmises that the stronger intermolecular and weaker intramolecular bonds in inorganic compounds cause this difference in behavior from typical organic samples.

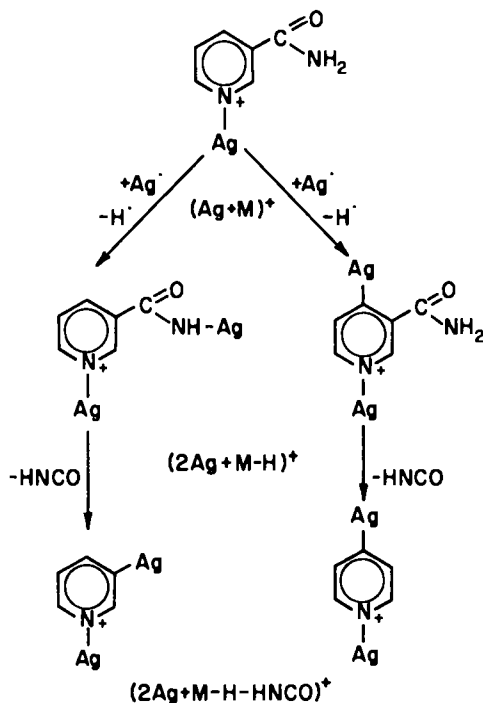
Catalysis. SIMS has been used to study systems of catalytic interest, including nickel complexes supported on insoluble polymeric and oxidic materials (70). Figure 12A is the SIMS spectrum of a nickel cyclopentadiene triphenylphosphine complex on silver. The nickel peaks are characteristic of the complex, while the $\text{Ag}(\text{PPh}_3)^+$ peaks indicate selvedge cationization of triphenylphosphine by sputtered Ag^+ . If alumina is added to the sample matrix, the resulting SIMS spectrum (Figure 12B) is, surprisingly, devoid of Ni-containing ions. This provides evidence of a strong Ni-alumina interaction. The ion $\text{Ag}(\text{PPh}_3)^+$ remains abundant, suggesting that Ni-phosphine bonds are cleaved preferentially to Ni-support bonds.

Studies of adsorbate interactions on catalytically reactive surfaces can also be carried out with SIMS. In one such study (71, 72), isotopic mixing was used to determine that carbon and oxygen atoms in RuCO^+ sputtered from a CO-saturated Ru(001) surface do not undergo exchange in the SIMS process. The SIMS spectrum of a Ru(001) surface after exposure to C^{18}O contains $\text{RuC}^{18}\text{O}^+$ and $\text{Ru}_2\text{C}^{18}\text{O}^+$ ions, and also RuC^+ , Ru^{18}O^+ , and Ru_2C^+ ions indicative of C-O cleavage. Figure 13 shows the SIMS spectrum of a mixture of ^{13}CO and C^{18}O on Ru(001). In

Table III. Ions present in the SIMS spectrum of $[\text{Cu}(\text{CNCH}_3)_4]\text{PF}_6$ and $[\text{Ag}(\text{CNCy})_4]\text{ClO}_4$ 1:1 with granulated graphite on graphite. Cy = cyclohexyl

Ions seen in neat $[\text{Cu}(\text{CNCH}_3)_4]\text{PF}_6$	Ions seen only in the mixture	Ions seen in neat $[\text{Ag}(\text{CNCy})_4]\text{ClO}_4$
$[\text{Cu}(\text{CNCH}_3)_4]^+$ (1)		
$[\text{Cu}(\text{CNCH}_3)_3]^+$ (1)		
$[\text{Cu}(\text{CNCH}_3)_2]^+$	$[\text{Cu}(\text{CNCy})_2]^+$ $[\text{Ag}(\text{CNCH}_3)_2]^+$ $[\text{Cu}(\text{CNCH}_3)(\text{CNCy})]^+$	$[\text{Ag}(\text{CNCy})_2]^+$
$[\text{Cu}(\text{CNCH}_3)_2+\text{HCN}]^+$	$[\text{Ag}(\text{CNCH}_3)_2+\text{HCN}]^+$ (2)	
$[\text{Cu}(\text{CNCH}_3)+\text{HCN}]^+$	$[\text{Cu}(\text{CNCy})+\text{HCN}]^+$	$[\text{Ag}(\text{CNCy})+\text{HCN}]^+$
$[\text{Cu}(\text{CNCH}_3)]^+$	$[\text{Cu}(\text{CNCy})]^+$ (3)	$[\text{Ag}(\text{CNCy})]^+$
$[\text{Cu}+2\text{HCN}]^+$		$[\text{Ag}+2\text{HCN}]^+$
$[\text{Cu}+\text{HCN}]^+$		$[\text{Ag}+\text{HCN}]^+$
Cu^+		Ag^+ $\text{C}_6\text{H}_{11}^+$ (Cy)

(1) Present in the neat compound, but not in the mixture
(2) Presence uncertain due to overlap with $[\text{Ag}(\text{CNCy})]^+$
(3) Presence uncertain due to overlap with $[\text{Cu}(\text{CNCH}_3)_2+\text{HCN}]^+$



Scheme 2. SIMS fragmentation of nicotinamide on silver. Reproduced with permission from Ref. 18. Copyright 1981, Elsevier Science Publishers B.V.

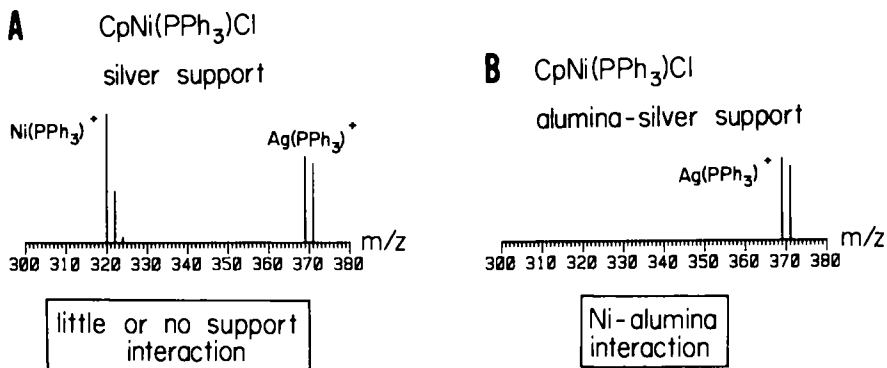


Figure 12. (A) SIMS spectrum of a nickel complex showing characteristic ions ($Cp = C_5H_5$). (B) SIMS spectrum of the same complex in an alumina matrix.

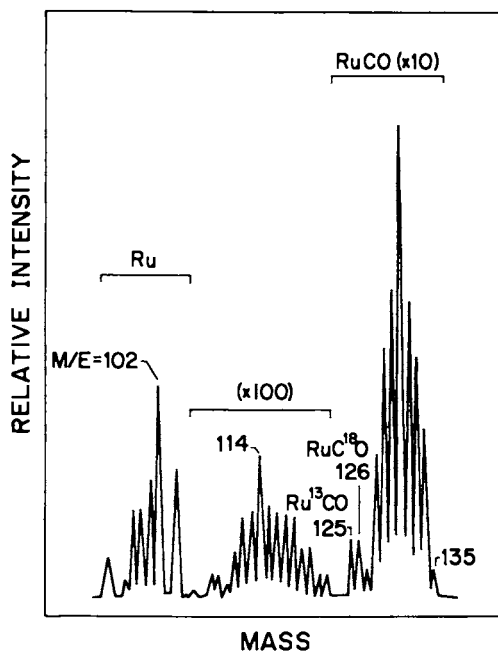


Figure 13. Isotopic labeling used to follow CO/Ru interactions by SIMS. Reproduced with permission from Ref. 71. Copyright 1982, The American Physical Society.

spite of the multiple RuCO isotope peaks in the region of interest, the lack of a peak at m/z 124 (which corresponds to $^{96}\text{Ru}^{12}\text{C}^{16}\text{O}^+$) clearly indicates that atomic mixing does not occur in this case. The small peak at m/z 135 is $^{104}\text{Ru}^{13}\text{C}^{18}\text{O}^+$ formed from trace $^{13}\text{C}^{18}\text{O}$ impurities and not by mixing. Hence, although small amounts of C^+ and O^+ are formed during ion bombardment, RuCO^+ is composed of intact CO groups, a result which supports intact emission of the molecule.

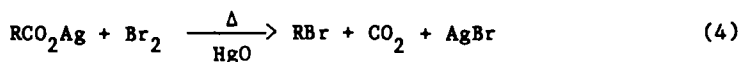
Imaging. Although ion beam imaging of atomic species is a well-developed method in inorganic SIMS (73, 74), imaging of polyatomic secondary ions, discussed on a number of occasions (1, 75), has only recently been demonstrated (76, 77). The former study employed an Ar^+ ion gun with a $30\mu\text{m}$ spot size to image polymer films. In the latter experiment a vacuum pump fluid, the perfluoro polyether fomblin, was deposited on the wires of a 500 line/inch nickel mesh. The primary ion source was a liquid metal ion gun (78) capable of producing a spot size less than $0.3\mu\text{m}$ in diameter. Mass analysis was performed with a high resolution double focusing mass spectrometer. Fomblin ions at m/z 131 and m/z 1281 were monitored to obtain two separate images, and in both images the supporting grid structure is clearly visible. Since signal at low mass was considerably stronger than that at high mass, the image quality for m/z 131 is much better than for m/z 1281. Nevertheless, high mass imaging was successful, and, as previously indicated (1, 75), one can envision future developments leading to in situ monitoring of biological materials.

Developing Areas

In addition to molecular imaging and such obvious advances as increased mass range and higher transmission analyzers, there are a number of new topics in molecular SIMS emerging as areas of interest. Not least of these is the study of chemical reactions at surfaces, which may be one source of the beam damage seen at high primary ion fluxes. A spectacular example of ion-beam-induced

reaction is seen in the thiophene-Ag system (79). If thiophene vapor is introduced into the vacuum system of a SIMS instrument concurrently with ion bombardment of a Ag surface, two unexpected ion series are observed (in some experiments). One of these series may be described by the general formula $[Ag+M+4H-n(14)]^+$, where M is thiophene and n equals 0, 1, 2, or 3. The cationized reduction product $[Ag+M+4H]^+$ is observed (n = 0); the expected $[Ag+M]^+$ adduct is not seen. Furthermore, for n = 1, 2, or 3, successive losses of CH_2 from the hydrogenated adduct are indicated. There are two processes occurring: complete hydrogenation (indicated by the addition of four hydrogens to the silver-cationized molecule) and hydrogenolysis (losses of CH_2). The presence of a large Ag_2HS^+ ion is evidence that extensive decomposition of thiophene is occurring and that the source of hydrogen is probably thiophene itself. This behavior was observed in three cases out of six, which implies a dependence on sample preparation. In the unsuccessful cases, the simple $[Ag+M]^+$ adduct was seen, with no contributions from hydrogenation or hydrogenolysis. Copper and platinum were also used as substrates in these experiments, but only $[Cu+M]^+$ and $[Pt+M]^+$ were observed.

Extensive C-C bond scission and rearrangements have been observed in systems other than thiophene-Ag. Table IV presents a number of such cases. The silver carboxylates (56) have already been mentioned briefly. A preponderance of CO_2 -containing adducts suggests a gas phase analogue to the classical Hünsdiecker reaction (Equation 4). The behavior observed with methyl acetate



vapor introduced over Cu foil may parallel the case of thiophene-Ag. In addition, dosing of metals with O_2 in a pretreatment chamber prior to SIMS analysis (80) also results in the formation of unexpected ions during sputtering. It should be emphasized that none of these data were obtained under extraordinarily harsh conditions; maximum primary ion current densities were on the order of $1 \times 10^{-8} \text{ A cm}^{-2}$. The extensive C-C cleavage, arising from implicitly high energy processes, differs from earlier molecular SIMS data (1) in which simple

Table IV. Summary of C-C scission in molecular SIMS

Compound and Conditions	Important Ions
thiophene vapor/Ag foil (M = thiophene)	$[Ag + M + 4H - n(14)]^+$ $[2Ag + M + 5H - n(14)]^+$ $n = 0, 1, 2, 3$
silver acetate on graphite (OAc = acetate)	$AgCO^+$ or $AgC_2H_4^+$, $AgCO_2^+$, $AgOAc^+$, Ag_2OAc^+ $Ag_2O_2COAc^+$, $Ag_2O_2COAcCH_2^+$
silver propionate on graphite (prop = propionate)	$AgCO^+$ or $AgC_2H_4^+$, $AgCO_2^+$, $Agprop^+$, Ag_2H^+ , Ag_2prop^+ , $Ag_2O_2Cprop^+$, $Ag_2O_2CpropCH_2^+$
silver benzoate on graphite (benz = benzoate)	$benzCO^+$ or $benzC_2H_4^+$, $Agbenz^+$, $Agbenz_2^+$, Ag_2H^+ Ag_2benz^+ , $Ag_2O_2Cbenz^+$
methyl acetate vapor/Cu foil	$CuOH^+$, $CuCO^+$ or $CuC_2H_4^+$, $CuCO_2^+$, $CuC_2H_4CO^+$, Cu_2H^+ , $CuMeOAc^+$, Cu_2O^+ , Cu_2OH^+ , $Cu_2C_2H_2^+$
methyl acetate vapor/Ag foil	$AgCO^+$ or $AgC_2H_4^+$, Ag_2H^+
copper acetate on graphite	$CuCO^+$ or $CuC_2H_4^+$, $CuCO_2^+$, Cu_2^+ , Cu_2H^+ , $Cu_2CH_3^+$, Cu_2OAc^+ , Cu_3^+
O_2 pretreatment; CH_3CHO on Ag foil at $-115^\circ C$	$AgCO_2^+$, $Ag_2CH_3^+$
O_2 pretreatment; CH_3CHO on Ag powder at $25^\circ C$	$AgCH_3^+$, AgO^+ , $AgCO^+$ or $AgC_2H_4^+$, $AgCO_2^+$, $Ag_2CH_3^+$, Ag_2O^+
O_2 pretreatment; C_2H_2 on Ag foil at $-115^\circ C$	$Ag_2C_2H^+$
O_2 pretreatment; C_2H_2 on Cu foil at $25^\circ C$	$Cu_3C_2^+$, $Cu_2C_2^+$, $Cu_2C_2H_2^+$

molecular species and relatively low energy fragmentations were apparent. Analytically, C-C scission is something to be avoided, but from a mechanistic viewpoint it may offer much insight. It is likely that at least some of these scissions occur at the surface, followed by cationization and combination in the selvedge. This is in contrast to the more common low energy unimolecular fragmentation which occurs in the free gas phase (vacuum). Strong chemisorption is one factor likely to favor surface bond scission.

Another area in which activity is expected to increase in the future involves the use of ion beams for modifying and/or synthesizing new materials. Ion implantation (81) has been used for some time in the semiconductor field, and sputtering of atomic materials (82) has a long history as a means for depositing uniform layers on surfaces. There have been no reports, however, of the sputter deposition of molecular species. A device has been constructed (83) for the purpose of sputtering organic materials, collecting them, and analyzing them by SIMS. Figure 14 illustrates the apparatus, which has been added to the sample preparation chamber of a commercial SIMS instrument. An ion gun is used to bombard a surface with a μA beam of 3keV Ar^+ . This surface--the primary surface--may be a metal or graphite foil and may have material deposited on it. Secondary ions sputtered from the primary surface are collected at the secondary surface, which is mounted at the end of a magnetic transfer rod for in vacuo transfer into the SIMS main chamber after sputtering. The secondary surface, like the primary surface, can be any vacuum-compatible material. A potential may be applied between the two surfaces to control the energy of the secondary ions.

In an early version of this apparatus, the secondary surface is 2 cm away from the primary surface; hence, sputtered neutrals, which may constitute the majority of the transferred particles, present a problem during materials transfer. Despite the pitfalls of this simple design, transfers of material have been made which show a dependence on secondary ion energy. For Ag sputtered on phenanthroline-Pt, a large $[\text{Ag}+\text{M}]^+$ peak was seen for 300 eV Ag ions, while for 10 eV Ag ions the $[\text{Ag}+\text{M}]^+$ peak was much smaller.

The next step in the experiment will be to incorporate mass analysis of material sputtered from the primary surface in order to reject neutrals and to be more selective in what is deposited on the secondary surface. It is hoped that catalytically useful materials, such as mass-selected small metal clusters, may eventually be deposited on surfaces. Furthermore, it may be possible to transfer reactive organic species (such as those in Table IV) to create new materials through control of the potential between the two surfaces.

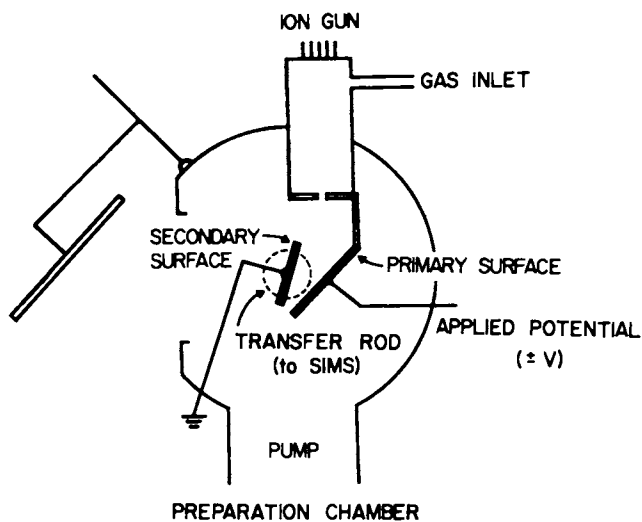


Figure 14. Apparatus to allow ion beams to be used in surface preparation. Reproduced with permission from Ref. 83. Copyright 1983, Elsevier Science Publishers B.V.

Acknowledgments

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Particle Bombardment as Viewed by Molecular Dynamics

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A classical dynamics model is used to investigate nuclear motion in solids due to bombardment by energetic atoms and ions. Of interest are the mechanisms of ejection and cluster formation both of elemental species such as Ni_n and Ar_n and molecular species where we have predicted intact ejection of benzene- C_6H_6 , pyridine- C_5H_5N , naphthalene- $C_{10}H_8$, biphenyl- $C_{12}H_{10}$ and coronene- $C_{24}H_{12}$. The results presented here show that the energy distributions of the parent molecular species, e.g. benzene, are narrower than those of atomic species, even though the ejection processes in both cases arise from energetic nuclear collisions. The bonding geometry also influences the ejection yield and angular distribution. The specific case of π -bonded and σ -bonded pyridine on a metal surface is discussed with comparisons between the calculated results and experimental data.

The bombardment of solids by energetic particle beams has attracted interest due to the ejection of large and novel species. These species can be molecules that are present in the original sample such as a dodecanucleotide (1) or clusters that are formed during the bombardment event, for example $[NO(N_2O_3)_3]^+$ ejected from solid nitrous oxide (2). Numerous other examples appear in these proceedings.

Our goal has been to understand the ejection mechanisms and the relationship of the clusters to the original configuration of atoms in the sample. Many mechanisms involving both the motion of the atomic nuclei and/or of electrons can be proposed to be responsible for ejecting the molecules. However, if a solid (or liquid) sample is bombarded by a heavy particle with energy in the 100-10000 eV range there must be energetic collisions between the atomic nuclei.

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Thus as a starting point for understanding the bombardment process we have developed a classical dynamics procedure to model the motion of atomic nuclei. The predictions of the classical model for the observables can be compared to the data from sputtering, spectrometry (SIMS), fast atom bombardment mass spectrometry (FABMS), and plasma desorption mass spectrometry (PDMS) experiments. In the circumstances where there is favorable agreement between the results from the classical model and experimental data it can be concluded that collision cascades are important. The classical model then can be used to look at the microscopic processes which are not accessible from experiments in order to give us further insight into the ejection mechanisms.

Briefly, the theoretical model consists of approximating the solid and possible adsorbed molecules by a finite array of atoms (3-12). Assuming a pairwise interaction potential among all the atoms, Hamilton's equations of motion are integrated to yield the positions and momenta of all particles as a function of time during the collision cascade. The final positions and momenta can be used to determine the experimental observables such as total yield of ejected particles, energy distributions, angular distributions and possible cluster formation. One advantage of the classical procedure is that one can monitor the collision events and analyze microscopic mechanisms of various processes.

Mechanisms of Cluster Formation

From the classical dynamical treatment, it is possible to examine the cluster formation mechanism in detail and to provide semiquantitative information about cluster yields. In general, these calculations suggest that there are three basic mechanisms of cluster formation (12). First, for systems with atomic identity such as metals, or atomic adsorbates on a solid, the ejected atoms can interact with each other in the near-surface region above the crystal to form a cluster by a recombination type of process (3-5). This description would apply to clusters of the type M_nO_m observed in many types of SIMS experiments. In this case the atoms in the cluster do not need to arise from contiguous sites on the surface, although in the absence of long-range ionic forces the calculations indicate that most of them originate from a circular region of radius ~ 5 angstroms. This rearrangement, however, complicates any straightforward deduction of the surface structure from the composition of the observed clusters. We have observed an Ar_{25} cluster to eject from solid argon via this mechanism (13). We would also speculate that the alkali halide clusters $(CsI)_nCs^+$ with n as large as 70 (14) also form by this basic mechanism.

A second type of cluster emission involves molecular species which can be as simple as carbon monoxide or as complicated as the dodecanucleotide mentioned above. In the first case, the CO bond strength is ~ 11 eV, but the interaction with the surface is only about 1 eV. Calculations indicate that this energy difference is sufficient to allow ejection of CO molecules, although ~ 15 percent of them can be dissociated by the ion beam or by energetic metal atoms (6). For such molecular systems it is easy to infer the original atomic configurations of the molecule and to determine the

surface chemical state. If CO were dissociated into oxygen and carbon atoms, for example, the calculations suggest that the amount of CO observed should drop dramatically.

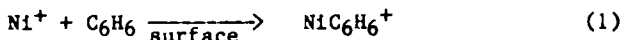
Although the basic principles behind this intact ejection mechanism can be illustrated with carbon monoxide, the extrapolation to large bioorganic molecules is not necessarily obvious. Calculations have been performed for a series of organic molecules adsorbed on a Ni(001) surface to understand the mechanisms of molecular ejection (8-12). The first molecules which have more than just a few atoms examined are benzene which π -bonds on a metal surface and pyridine which can either π -bond or σ -bond on a metal surface. Larger structures, whose sizes approach the diameter of bioorganic molecules, are naphthalene, biphenyl and coronene whose adsorption structures are unknown. All the molecules except pyridine are assumed to π -bond on the surface.

In all cases we find that the molecular species may be ejected intact. From our theoretical calculations, three factors favor this process (8-9). First, a large molecule has many internal degrees of freedom and can absorb energy from an energetic collision without dissociating. Second, in the more massive framework of a large organic molecule, individual atoms will be small in size compared to a metal atom; thus, it is possible to strike several parts of the molecule in a concerted manner so that the entire molecule moves in one direction. Finally, by the time the organic molecule is struck, the energy of the primary particle has been dissipated so that the kinetic energies are tens of eVs rather than hundreds or thousands of eVs. These three factors are equally valid for the ejection of either carbon monoxide, benzene or coronene. However, in the cases of the larger molecules, we found that often 2-3 metal atoms would strike different parts of the molecule during the ejection process. The time for the molecules to eject after the primary particle has hit the sample is less than 200 femtoseconds (fs; $1\text{fs}=1\times 10^{-15}\text{s}$). This intact ejection mechanism for molecules can be applied to molecular solids. We find for the bombardment of ice shows that the water molecules also eject intact (15).

It is difficult to make quantitative determinations of the fragment yields because the forces that govern all the rearrangement channels are not known. However, there is one interesting feature related to fragmentation that we have observed. Most of the fragments formed from direct collisions within ~ 0.2 ps are the parent molecule minus an H, CH, or C_2H_2 . These arise from an energetic collision that rips off part of the molecule. In the case of biphenyl however, a severing between the two rings is observed to occur with some frequency. Thus the structure of the molecule influences the nature of the direct fragmentation process. These small CH type species will undoubtedly be formed during the ion bombardment process. To be detected, however, in a conventional SIMS or FABMS apparatus they must be formed as an ion. Within this classical model we are unable to predict the charge fraction.

The final mechanism for cluster ejection is essentially a hybrid mechanism involving both intact ejection and recombination. In the case of CO on Ni_3Fe , we find that the observed NiCO , Ni_2CO

and NiFeCO clusters form by a recombination of ejected Ni and Fe atoms with ejected CO molecules. There is apparently no direct relation between these moieties and linear and bridge-bond surface states. In the case of cationized species such as NiC_6H_6^+ ions, we propose a reaction of the type



The presumption that the Ni supplies the charge is based on the fact that no C_6H_6^+ is observed (16) and that the ionization potential of Ni is less than that of benzene.

This final hybrid mechanism may be responsible for the formation of the dimer ion of the dodecanucleotide (1) or of water clusters (17). Each molecular unit ejects intact and then interacts with other molecules in the near surface region to form the cluster entities. In the case of $(\text{H}_2\text{O})_2$ clusters our calculations indicate that the two H_2O molecules originate from mostly adjacent sites on the surface (15). This is a consequence of the relatively weak H_2O - H_2O interaction. Ionic clusters such as $(\text{H}_2\text{O})\text{H}^+$, however, can form from an H_2O molecule and an H^+ ion that were further apart on the surface.

The fact that the composition of the ejected clusters may be different from the original arrangement of surface atoms is somewhat discouraging. As it turns out, however, there are situations where the precise nature of the rearrangement can be predicted theoretically. One example involves the measured O_2^-/O^- ratio as a function of oxygen coverage on Ni(001). This ratio is four times higher for 50 percent oxygen coverage [c(2x2)coverage] than for 25 percent oxygen coverage [p(2x2)surface], a change that is also calculated with the model (18). The reason for this effect is that there are no closely neighboring oxygen atoms on the p(2x2) surface, and the O_2 formation probability is much lower. Concepts of this sort may be useful in testing for island-growth mechanisms and distinguishing them from those that proceed through several distinct phases.

Energy Distributions

The energy distribution of atomic species ejected in bombardment experiments are characterized by a peak at 1-5eV and a high energy tail that goes approximately as E^{-n} where $n \approx 2$. This distribution is characteristic of a non-equilibrium collision cascade. The energy distributions of the parent molecular species are much narrower, however, and often terminate at $\sim 10\text{eV}$. Shown in Figure 1a are experimental energy distributions for Ag^+ , C_6H_5^+ and C_2H_2^+ ions ejected from a system with a monolayer of benzene adsorbed on a Ag(111) crystal face (19). Since the molecular species is ejecting during the same collision cascade as the Ag^+ ions and on the same timescale one would expect the distribution of collision energies that cause ejection to be the same for the Ag atoms and

the C_6H_6 molecules. However, the energetic collisions with the molecular species can and do cause fragmentation. Thus the energetic benzene molecules are depleted. The fragments then should have a distribution at higher energies as is illustrated by the $C_2H_2^+$ fragment energy distribution shown in Figure 1a. Note that the peak of the $C_2H_2^+$ distribution is at a higher energy than that of the $C_6H_5^+$ distribution. Since the peak position can be correlated to the binding energy of the species to the surface, the peak of the $C_2H_2^+$ distribution should be higher since its binding energy includes two C-C bond energies. The energy distributions from the calculations (Figure 1b) illustrate the same physical phenomena.

It is tempting to use the energy distributions of the ejected particles as a key to understanding the mechanisms responsible for the desorption. Care must be taken, however, as collision cascades can give rise to at least three distinctive shapes of energy distributions as shown in Figure 1. (The calculations also predict the distribution of metal atoms to have a high energy tail.) In fact the calculated C_6H_6 distribution of Figure 1b can be reasonably approximated by a Maxwell-Boltzmann form even though a thermal equilibrium is not present in the solid during the ejection event. The calculations indicate that energy distributions of elemental (and preferably both the neutral and charged) species could possibly be the most useful for comparing to the different experimental mechanisms as these particles cannot be fragmented in energetic collisions. Even here, however, one can obtain energy distributions from SIMS experiments that fall off more rapidly than E^{-2} if low energy (<250 eV) primary ion beams are used (20).

Matrix Effects

The composition of the solid or matrix which is being bombarded has a large influence on the types of species observed to eject. This is true not only for the ionization process but also for the nuclear motion. Shown in Figure 2 are SIMS spectra of benzene taken for three different substrates. The data in Figure 2b was obtained for Ar^+ ion bombarded Ni(001) exposed to 3 langmuirs of benzene (16). This dose corresponds to approximately one monolayer coverage. This spectrum contains only the Ni^+ , Ni_2^+ and $NiC_6H_6^+$ ions. Karwacki and Winograd also performed SIMS experiments for C_6H_6 adsorbed on Ni(001) where they dosed the surface with 2100 langmuirs of benzene (16). This SIMS spectrum is shown in Figure 2c. Here the multiple layers of benzene attenuate the Ni^+ , Ni_2^+ , and cationized $NiC_6H_6^+$ peaks. This spectrum, however, does contain hydrocarbon fragments of lower masses.

Two SIMS experiments have been performed on solid benzene at a temperature of 77 K (17,21). The mass spectrum from Lancaster et al. is shown in Figure 2d. They observe peaks at all masses corresponding to $C_nH_m^+$ where $n < 30$. The predominant peaks are the C_1 , C_2 , and C_3 species, in agreement with the work of Karwacki and Winograd (Figure 2c). We believe the reason we do not observe these $C_nH_m^+$ species with $n > 6$ in the calculations is due to the low density of benzene molecules on the Ni surface.

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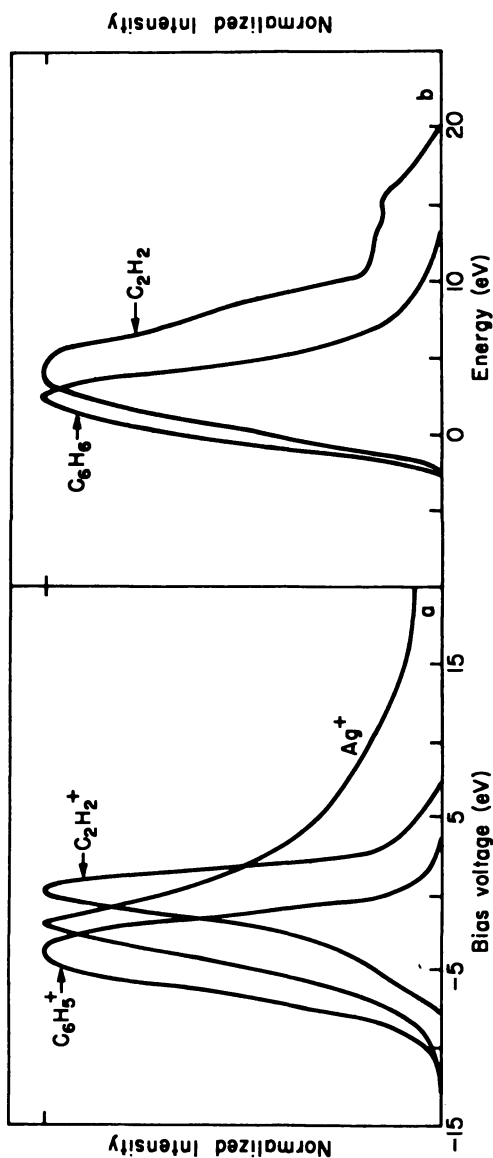


Figure. 1. Energy Distributions. a) Experimental Ag^+ , C_6H_5^+ and C_2H_2^+ ion intensities from one monolayer of benzene adsorbed on $\text{Ag}(111)$ plotted versus the voltage on the sample. The primary particle is Ar^+ with energy 1 keV incident on the sample at a polar angle of 45° . The secondary particles are collected at a polar angle of 60° . The raw data has been smoothed. This data has been graciously provided by D. W. Moon, R. J. Bleiler and N. Winograd prior to publication. b) Calculated C_6H_6 and C_2H_2 energy distributions from one monolayer of benzene on $\text{Ni}(001)$. All ejected particles have been counted. The energy resolution is 5eV. The calculations are described in ref. 9. Reproduced with permission from Ref. 12. Copyright 1983, Elsevier Science Publishing Co.

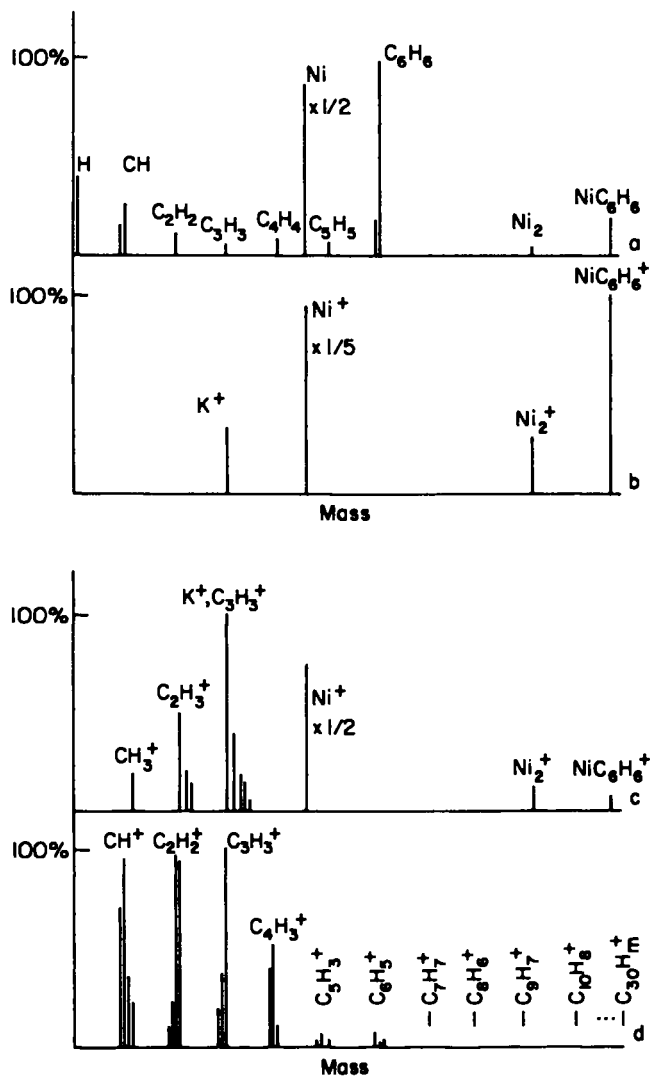


Figure 2. Benzene mass spectra. The most intense peak in each grouping has been identified. a) Calculated, (9). b) Experimental SIMS, 3 langmuirs of C₆H₆ on Ni(001), (16). c) Experimental SIMS, 2100 langmuirs of C₆H₆ on Ni(001), (16). d) Experimental SIMS, solid benzene (17). Reproduced with permission from Ref. 12. Copyright 1983, Elsevier Science Publishing Co.

It is obvious from Figure 2b-d that the sample preparation strongly affects the mass spectrum. The low coverage study appears to be the one where the parent species can be most easily identified as long as there is an energetically favorable means of ionization, e.g., cationization. The solid benzene studies are interesting in that a variety of large clusters are observed. However, if the sample were of an unknown compound, it would be difficult to extract the parent species from Figure 2d. The calculated spectrum (Figure 2a) predicts the parent molecule, C_6H_6 , to be the most abundant organic species. The comparable experimental data, Figure 2b, however, has no $C_6H_6^+$ peak but a large $NiC_6H_6^+$ peak. Here then, the electronic environment influences which species are observed.

Molecular Orientation Effects: Benzene vs. Pyridine

It is of interest to compare the ejection mechanisms for molecules bonded to the surface with different orientations. In benzene, the interaction with the surface is shared among six carbon atoms via the π -electron cloud. In pyridine, however, the bonding occurs almost totally through the nitrogen atom while the remainder of the molecule is pointing away from the surface. The most striking difference between the two cases is that the computed yield of molecular species for the pyridine system is extremely low (9). The reasons for the major difference in yields for these two structures is clear from an analysis of the trajectories that lead to molecular ejection of pyridine. Very simply, pyridine ejection requires the specific cleavage of a N-Ni bond during a single collision. When a carbon atom is struck, the molecule either stays on the surface or tends to dissociate. There appears to be no efficient modes of transferring the energy of collisions with the molecule into translation away from the surface. Obviously the original structure of the organic molecules, then, affects the ejection and fragmentation processes. One would not necessarily expect similar spectra from a sample of a monolayer of organic molecules on a metal, a liquid, or an ordered solid.

These orientational effects have recently been confirmed in SIMS measurements of pyridine and benzene adsorbed on Ag(111) (22). In this system the benzene π -bonds to the surface while the pyridine π -bonds at low coverages but rearranges at higher coverages to σ -bond to the surface. The intensity of the $AgC_6H_6^+$ ion monotonically increases as the benzene coverage on the silver surface is increased to one monolayer. The $AgC_5H_5N^+$ and $C_5H_5NH^+$ ion intensities, however, initially increase and then decrease as the molecule rearranges on the surface, and finally increase again as the pyridine coverage is increased to one monolayer.

The arrangement of the molecules on the surface also influences the angular distributions of the ejected species (22). The polar angle distributions of various ejected ions for four systems -2.5 L benzene (monolayer), 4.5 L pyridine (monolayer, σ -bonded) 0.15 L pyridine (π -bonded), and 12 L thiophene (monolayer) on Ag(111) have been measured. The results of these distribution measurements are illustrated in Figure 3. For

monolayer benzene and for low coverage pyridine where the molecules are believed to lie flat on Ag(111), the polar angle distribution of $(M-H)^+$ (benzene) and $(M+H)^+$ (pyridine) are broad with a peak at $\theta = 20^\circ$ measured with respect to the surface normal. At the onset of the change in bonding configuration, however, the polar angle distribution of the $C_5H_5NH^+$ ion sharpens dramatically and the peak moves to $\theta = 10^\circ$. It appears that the array of σ -bonded pyridine molecules provides a means of focusing the direction of ejection of the pyridine molecules. Further, the polar angle distribution of the high kinetic energy ions (6-10eV) ejected from the σ -bonded pyridine structure is 20-30% wider than the distribution of the low kinetic energy ions (3-7eV) as is shown in Figure 1b. This trend toward wider polar angle distributions for faster moving particles is counter to that observed for atom ejection. The polar angle distribution of thiophene, is narrow with a peak at $\theta = 10^\circ C$, indicating that it also is σ -bonded to the surface.

In this case it appears that the σ -bonded pyridine molecules are channeling the ejecting pyridine molecules into the vertical direction (23). One example of how this blocking can significantly affect the trajectory of an ejecting pyridine molecule is illustrated in Figure 4. Only the species (one Ar^+ ion and two pyridine molecules) directly involved in this particular ejection process are shown. In this example the metal substrate plays no direct role in ejecting the molecule. The grid lines are drawn between the nearest-neighbor atoms in the first plane of the microcrystallite. The elapsed time during the collision process is shown in fs ($1\text{ fs}=1 \times 10^{-15}\text{ s}$). The initial positions of the atoms are drawn in Figure 2 (0 fs). At 33 fs the Ar^+ ion, which has backscattered from the surface, is colliding with 3 carbon atoms in the target pyridine molecule. The kinetic energy of the center of mass of this pyridine molecule is 11.6 eV and its molecular axis is oriented at a polar angle of $\theta=66^\circ$ from the surface normal. At 85 fs the ejecting pyridine molecule collides with a neighboring pyridine molecule and dissipates a fraction of its momentum. At the final stage of the sputtering process (120 fs), the pyridine molecule ejects molecularly, even though distorted, at a polar angle of $\theta=31^\circ$ with 1.40 eV of kinetic energy. Due to the blocking by a neighboring pyridine molecule, the polar angle of the ejected pyridine molecule is altered from 66° to 31° . The walls created by pyridine molecules are not completely rigid as indicated by the distorted molecule shown on the left in the 120 fs frame. Therefore, a pyridine molecule ejecting with a large kinetic energy will not feel a strong enough force to channel it completely into the upward direction. The polar angle distribution of the high energy ejected particles is thus broader than that of the low energy ejected particles. This mechanism is distinct from that found with atom ejection. In this latter case, the energy dependence of the azimuthal distribution is related to the time of ejection and consequently to the amount of surface structure present when the atom ejects. Note that for the π -bonded benzene system, there are no channels to orient the ejecting molecules.

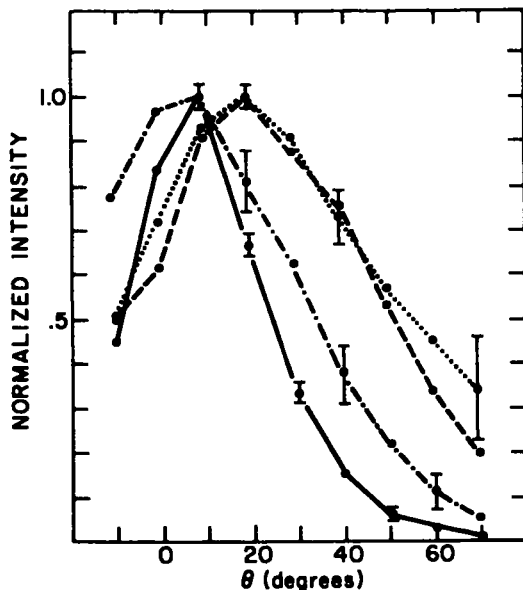


Figure 3. Normalized polar angle distribution of molecular ion yields for 4.5 L pyridine (—, $(M+H)^+$), 0.15 L pyridine (---, $(M+H)^+$), 2.5 L benzene (····, $(M-H)^+$), and 12 L thiophene (-·-·-·-, M^+) on Ag(111) at 153K. The pyridine and benzene data is from (22) and thiophene data has been supplied by the same authors.

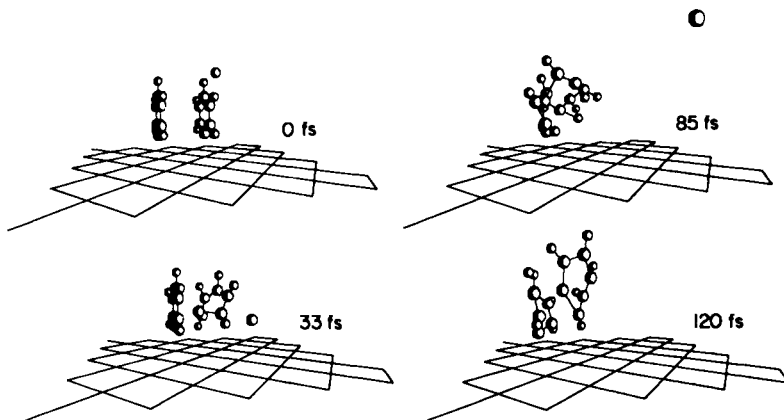


Figure 4. Change of the ejection angle of a sputtered pyridine molecule (right one) due to the blocking by a neighboring pyridine molecule (left one). The labels are in fs where $1 \text{ fs} = 1 \times 10^{-15}$ second. (0 fs) Initial positions of the atoms. (33 fs) The backscattered Ar^+ ion collides and ejects the pyridine molecule at a polar angle of $\theta=66^\circ$. (85 fs) The ejecting pyridine molecule is blocked by a neighboring pyridine molecule. (120 fs) Finally, the ejection polar angle is changed to $\theta=31^\circ$. Both the sputtered molecule and the blocking molecule are distorted. Reproduced with permission from Ref. 23. Copyright 1985, Elsevier Science Publishing Co.

Fragmentation

There has been considerable speculation as to whether the observed fragments form primarily from direct collisions at the surface (i.e. within $\sim 0.2 \times 10^{-12}$ s after the primary particle has struck) or from dissociation of larger species during the flight to the detector (often as long as 10^{-4} s). The calculations show that it is definitely possible to form numerous fragments in direct collisions at the surface (Figure 2a). From the calculations we have estimated that approximately three quarters of the ejected benzene molecules have less than 5 eV of internal energy (9). There is a reasonable probability that these vibrationally colder molecules will remain intact. The energetic molecules, on the other hand, will undoubtedly dissociate.

At this stage it is necessary to design clever experiments or theoretical approaches to help elucidate the different possible modes of fragmentation. Recently Moon (24) has proposed a method of examining the polar angle distributions as a means of differentiating between the fragmentation schemes. He finds that for chlorobenzene adsorbed on Ag(111) that the $C_6H_5^+$ and Cl^- ions probably form by direct collisions on the surface. For the chlorobenzene as well as benzene and pyridine adsorbed on silver, he found that neither molecular or fragment ions formed by gas phase decomposition of a cationized species.

In the case of the alkali halide clusters (14), recent work has shown that the oscillations in ion intensity with cluster size are due to dissociation of metastable species during the flight to the detector (25). Spectra taken 0.2 μ s after bombardment exhibit a monotonic decrease in ion intensity with increasing cluster size. Spectra taken after 70 μ s, however, show an increase in the $(CsI)_{13}Cs^+$ ion intensity and a decrease in the $(CsI)_{14}Cs^+$ and $(CsI)_{15}Cs^+$ ion intensities. Here then, decomposition of larger species during the flight to the detector has a noticeable effect on the cluster yields. These experiments though make no statement as to how the clusters are initially formed near the surface.

Closing Statements

A classical dynamics model has been developed to investigate the importance of collisional processes in heavy particle bombardment experiments. This procedure is very powerful for describing collisional events and provides a working hypothesis against which experimental data can be compared. We have shown numerous examples from SIMS experiments where the calculations have fit experimental data very well. The time has come for the experimentalists to conceive and execute experiments aimed at uncovering the fundamental processes involved in the SIMS and FABMS procedures.

It should be noted that various researchers have different goals for using and understanding the ion bombardment process. There are those who are using the technique to obtain information about a molecule that they have placed on the surface. That is, they want a mass and possibly a structure determination. Other researchers are primarily concerned with determining the elemental composition of the sample while others use the technique to measure

the geometrical arrangement of the atoms and molecules on the surface. Another area of interest is to probe the electronic processes involved when an atom or molecule is in the near surface region. Although these goals are quite varied the fundamental processes are intermingled. To understand our own area of interest we need to understand all of the experimental results and the detailed events occurring on the microscopic level.

Acknowledgment

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Role of Intermolecular Interactions in the Desorption of Molecular Ions from Surfaces

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Intermolecular interactions of surface molecules can modify the spectrum of molecular ions that are desorbed when the surface is excited. These interactions may be important in all of the particle induced desorption processes including SIMS and FAB and may involve the manner in which excitation energy from the primary ion is dissipated into the medium. A brief account of some experiments being carried out to gain a better understanding of the energy relaxation process for high and low energy ion bombardment is given. Experiments using Langmuir adsorption to control intermolecular spacing between Rhodamine molecules are described with a demonstration of the influence on the mass spectra of these species. Finally, some experiments on the desorption of molecular ions of insulin will be discussed.

This symposium is devoted to a discussion of the similarities and differences of SIMS and FAB, the two most popular particle-induced desorption methods. There is another method called 252-Californium plasma desorption mass spectrometry (252-Cf PDMS) which was introduced in 1974 that bears a strong resemblance to these methods primarily from the similarities of the main features of the mass spectrum of the desorbed molecular ions (1). It is probably for this reason that 252-Cf PDMS was included in this Symposium because it may be part of the complex picture of how these methods work. That the mass spectra are remarkably similar in most cases, particularly for complex biomolecules, is an important observation because it implies that the particular molecular excitations that are operating in the emission-ionization process may be insensitive to the details of the primary energy form brought in by the incoming ion or atom, that it does not matter whether the primary particle is an ion, atom, photon, or is at keV or 100 MeV energy. This remarkable universality is one of the puzzling aspects of the problem. Models have been introduced to give some physical picture to what might be going on and while

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these have given conceptual insights they may also have contributed to the present state of confusion. The problem is that there are not enough experimental facts on which to base a sound model. However, there are some data, some from fields not associated with mass spectrometry, that may be giving some clues to what is going on. The first part of this paper includes some of these results. The second part describes some of our recent studies that relate to the role of intermolecular interactions in mediating the emission-ionization process. Finally, results on the desorption of massive molecular ions of biopolymers will be discussed; there seem to be some real differences between low and high energy particle-induced emission for these species.

The Energy Deposition Process

It is now clear that it does not matter whether a primary particle is neutral or charged and that the fundamental differences between SIMS and FAB lie within the use of a solid vs. liquid matrix. In subsequent discussions in this paper no distinction will be made between neutral and ionic primary particles. The SIMS and FAB method utilize primary ions in the 5-20 keV regime where nuclear stopping is known to be the primary mechanism for energy deposition. The initial impact triggers a collision cascade which results in the sputtering of secondary atomic ions with a relatively high kinetic energy distribution, a signature of processes supported by an energetic collision cascade. This phase of the interaction is well supported by experimental data and a quantitative theory, the Sigmund sputtering theory (2). Molecular ions emitted in the process have a much lower kinetic energy distribution which cannot be fitted to Sigmund theory suggesting that they are not emitted during the part of the collision cascade that produces atomic ions (3). Recently, Standing studied the emission of molecular ions of simple amino acids as a function of primary ion energy using ions ranging from Li to Cs and energies from 1 to 16 keV (4). There were some important conclusions in this study: molecular ion yields closely follow the amount of energy brought in by the nuclear stopping mechanism and for Li primary ions where nuclear and electronic stopping both contribute to the energy deposition it was the total energy deposited that was the significant factor in determining the molecular ion yield. Electronic excitation is different from nuclear excitation because the excitation involves promoting electrons in the matrix to higher excitation states whereas nuclear excitation moves atoms from their positions in the matrix. The Standing results give experimental evidence that despite these large differences in the initial form of excitation of the matrix, the emission of secondary molecular ions is insensitive to these differences.

A considerable amount is known about details of the primary events in electronic excitation. Electronic excitation cross sections are dependent on the charge and velocity of the incident primary ion. Both of these parameters have been confirmed to be the important variables in the emission of secondary molecular ions under bombardment by ions in the 50-100 MeV regime (1 MeV/u) (5-6). The excitation promotes electrons within atoms and molecules to very high energies resulting in ionization and emission of secondary electrons (up to 50 per incident ion) (7). The excitation of electrons in core

levels produces vacancies that are refilled by Auger processes resulting in atomic ions with multiple charge states. These are part of the spectrum of atomic ions emitted in 1 MeV/u ion bombardment and are totally absent in SIMS spectra using the same targets. Weller has recently made this comparison and has extended the energy range for SIMS primary ions to 100 keV (8).

High energy ions entering a solid produce a linear damage track of about 15 microns in length that can be visualized by electron microscopy (9). The linear energy transfer (LET) to the matrix is a measure of the density of energy deposition which is a function of the charge and velocity of the primary ion. By varying the charge of the primary ion and with a knowledge of the charge equilibration process, Voit has shown that only the energy deposited within the top 6-10 molecular layers of a valine matrix is contributing to the emission of secondary molecular ions. This means that for a 100 MeV fission fragment ion, as is used in 252-Cf-PDMS, only 50 keV is used in the emission of secondary ions (LET=10,000 eV/nm) but this is concentrated in a very small volume at the surface, and in a subfemtosecond time frame, giving an effective power density of 10^{15} watts/cm². The profile of a heavy ion track contains an inner core with a radius of 0.1 nm that includes all the atoms and molecules that were excited by the primary ion. This is surrounded by a cylinder of energetic electrons (delta rays) extending to 1 nm that were ejected from the inner core in the initial excitation process (10). The lifetime of this track structure is approximately 10^{-17} s. There is not much experimental information as to what happens after this.

The Energy Dispersion Process

While the primary excitation processes for both keV and MeV ions is well understood, little is known on how this energy is transformed into the form required for the ejection of secondary molecular ions. In both cases, the volume excited, if crystalline, is melted and freezes to an amorphous state (11-12). This is an experimental observation indicating that at some stage in the energy dispersion lattice vibrations are excited to a level where intermolecular bonds are broken. We have some experimental clues as to what happens after the primary track is formed by a high energy ion. If the track is formed in a semiconductor, it is possible to collect and measure the electron current produced in the generation of electron-hole pairs. This is the basis for the operation of semiconductor detectors used in nuclear spectroscopy. For ions with a high LET, the density of electron-hole pair formation is so great that recombination processes occur (non-linear processes) resulting in a loss of electron current (ionization defect) (13). When the matrix is an insulator, energy transfer is mediated by various forms of excitons which can propagate through the solid. The exciton concept was first introduced by Forster as a mechanism for energy transfer in solids. The existence of excitons (quanta of electronic excitation) is now well documented and its role in secondary ion emission as now been experimentally verified for argon atoms sputtered by MeV He ions from argon ice (15). Exciton migration to fluorescent sites in plastic scintillators is the mechanism of the operation of plastic scintillator crystals as particle detectors for nuclear spectroscopy.

multiphonon absorption into the bonds holding the molecule to the surface (22). The key measurements to be made that would contribute to an understanding of this phase of the problem are the kinetic energy and angular distribution of the ejected ions and molecules. Winograd has made these measurements for SIMS using well-defined adsorbate-substrate systems and Wien has made similar measurements for 252-Cf-PDMS (23,24).

Perhaps the most confusing aspect of the problem is the ionization mechanism. It is difficult to control the matrix to the level where significant progress can be made in understanding what processes are involved that produce the ionized molecule. The simplest species to study is the preformed ion, a species in the condensed phase that has lost or gained most of an electron as a consequence of electronegativity differences. Whether it remains an ion in the emission process depends on the electronic interactions operating at the surface between adsorbate and substrate (25). The larger the ion, the greater is the probability that the preformed state is retained. Large organic cations (quaternary ammonium salts) and large organic anions (oligonucleotides) are examples. Small anions such as Cl^- in NaCl are apparently emitted as neutral species while multiply charged species are emitted as singly charged ions (26,27). These observations suggest that surface processes can play a role in determining the ultimate charge state of a desorbed species.

When one considers the role of the matrix in the particle-induced emission of secondary ions it is no wonder that it is so difficult to unravel all the processes that take place. The matrix is the medium in which the primary excitation occurs. It must also disperse some of that energy to sites at the surface where secondary ion emission occurs. It must provide the species to be desorbed and at the same time mediate the ionization process. In an attempt to understand these complex coupled processes we have tried to simplify the system by first selecting a homogeneous substrate for the energy deposition and then studying the ionization-emission process for species that are present as a submonolayer on the surface (28).

Polymeric Surfaces as Substrates

In a 252-Cf-PDMS measurement, the sample consists of a thin metallized backing on which the sample is deposited using techniques such as the electrospray method (29). The conducting surface is required in the measurement because it establishes the electric field lines through which the ejected ions are accelerated. We have recently found that if we reverse the metallized polymer film so that the polymer side is the desorption surface, it is still possible to obtain good quality mass spectra that show no evidence for electrostatic charging. This geometry is depicted in Figure 1. The significance of this is that the polymer surface can be utilized to selectively adsorb solute molecules from solutions in a manner analogous to the adsorption of solutes onto the stationary phase in liquid chromatography columns. The number density of solute molecules on the surface can be controlled by varying the solution concentration and solvent type. In the first experiments the native polymer surface of Mylar (polyethylene terephthalate) was employed and solute molecules were adsorbed onto the Mylar surface from

When these detectors are used for the high LET fission fragments the light output is considerably reduced relative to other ions with comparable energy but lower LET (16). This has been attributed to the quenching of exciton states in the heavy ion track due to their high density. These radiationless transitions deposit their energies into vibrational excitation within the matrix. The exciton model is well developed. There are many different types of excitons (e.g. atomic and molecular). Kimura has shown that alkali halides excited by high energy ions first form atomic excitons that localize on individual ions within the crystal lattice but these ultimately decay into molecular excitons that are associated with diatomic states and which fluoresce with a characteristic spectrum (17).

An attractive feature of the exciton model is entry into the family of exciton states can be made by either electronic excitation (transverse excitons) as with high energy ions or by collisional processes (longitudinal excitons) and both could decay into the same pattern of electronic and vibrational excitations (18). This could provide a microscopic explanation for the similarities of SIMS and 252-Cf-PDMS mass spectra. If the emission of secondary ions from surfaces is mediated by exciton-phonon processes, the energy dispersion will be influenced by physical features of the matrix (degree of crystallinity and purity) which are not easily controlled. For species with a multiplicity of intermolecular interactions and which do not exist as ions in the solid state, the probability for secondary molecular ion formation is dependent on properties of the matrix which are not understood (19). The relationship of molecules at the surface which are participating in the formation of secondary ions with neighboring molecules may also be important in the final stages of the energy dispersion process. Some experiments directed to this question will be described later in this paper.

The Emission-Ionization Process

The fact that secondary ions are indeed observed in SIMS (FAB) and 252-Cf-PDMS means that some of the energy dispersion appears in the form needed to effect emission of molecular species from the surface which ultimately appear as ions in a mass spectrometer. Standing has made the point that instrumental parameters may be influencing the ion formation step (20). The time-of-flight mass spectrometers used in 252-Cf-PDMS and in some SIMS studies are primarily sensitive to ion-forming processes that occur at or very close (10 nm) to the surface while in most magnetic sector and quadrupole instruments, the ionization region may be considerably extended to the point where gas phase ion-molecule reactions might occur. This ambiguity may be the source of some of the disagreements with regard to where the ionization is occurring. Gas phase ion-molecule reactions such as occur in chemical ionization are better understood than the processes that occur at surfaces. The mechanism of the emission process has been the subject of several theoretical treatments. One of these considers that the emission process is associated with the later stages of the collision cascade and that even in the case of an initial primary electronic excitation a collision-like cascade is developed (21). Another approach considers the energy to be so well dispersed that the emission site is vibrationally excited. The molecule is ejected from the surface as a consequence of a

solutions of polar solvents (water, methanol, ethanol) utilizing the hydrophobic interaction (30). In subsequent experiments the Mylar surface was chemically modified by coating with polymers having different functional groups (cation exchange, anion exchange) so that the adsorption properties could be varied over a wide range. This arrangement of substrate-adsorbate made it possible to utilize a fixed homogeneous matrix where the primary energy deposition and dispersion occurred. In addition, by varying the concentration of the solution, it was possible to produce films with different number densities of solute species. The questions to be answered initially were: does the nature of the substrate influence the mass spectrum of ions that are emitted from the surface? Does the surface concentration of solute molecules influence the mass spectrum of secondary ions in ways other than effecting the overall intensity of the ions?

Rhodamine 6-G. This molecule was selected for the first study because its adsorption characteristics on surfaces had already been studied. The fluorescence characteristics of this molecule when adsorbed on a surface provides an internal measure for the average distance between molecules (31). In addition the solid exists in the form of a hydrochloride salt and the cation exists essentially as a large preformed ion. The structure of the molecule has a large aromatic component so that adsorption on the Mylar which also has an aromatic ring in its structure is favorable. The 252-Cf-PDMS spectrum of an electrosprayed deposit of this molecule is dominated by an intense molecular ion with very little fragmentation. The study involved the preparation of a series of ethanol solutions of Rhodamine 6-G with concentrations varying from 10^{-5} M to 10^{-2} M. A 100ul aliquot was deposited on the surface of the Mylar and equilibrated for a few minutes. The droplet was then removed and the sample was inserted into the mass spectrometer for mass analysis. This procedure was repeated using the different solution concentrations giving a series of targets with increasing concentrations of the solute on the Mylar surface. Figure 2 shows the 252-Cf-PDMS spectrum of one of the Mylar films containing Rhodamine 6-G adsorbed from a 10^{-5} M solution. Figure 3 is a plot of the intensity of the Rhodamine 6-G molecular ion as a function of solution concentration. The reproducibility of the measurement is 10%. An independent measurement of the number density of Rhodamine 6-G by a Beer-Lambert absorbance confirmed the results of earlier measurements of Garoff using optical spectroscopic techniques (31). The intensity-concentration curve is characteristic of a Langmuir adsorption mechanism. It was possible to deduce from the linear portion of the curve that the effective region of excitation for ion emission is relatively small, much smaller than the 20 nm diameter damage areas measured by electron microscopy for equivalent samples (12). If the excitation area were large, at a particular number density the area would have intercepted more than one molecule. This would have resulted in a positive deviation in the linear portion of the adsorption curve and none was observed. Two effects were observed that relate to the influence of the number density at the surface on the nature of the mass spectrum of secondary ions. First, the Cl counter ions were only observed when monolayer coverage was realized. This implies that Cl is emitted as a neutral species at

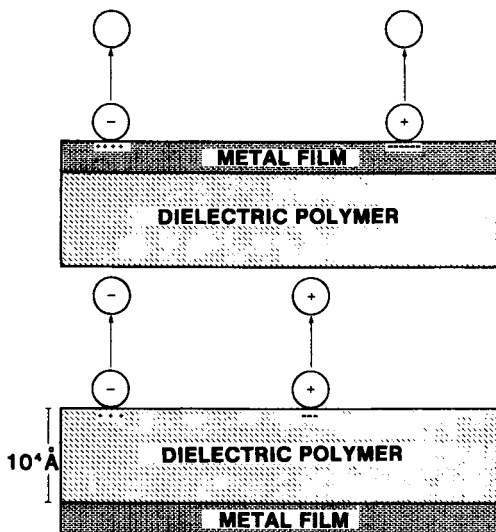


Figure 1: Schematic representation of the aluminized Mylar surface. The polymer side of the film is used for the adsorption studies.

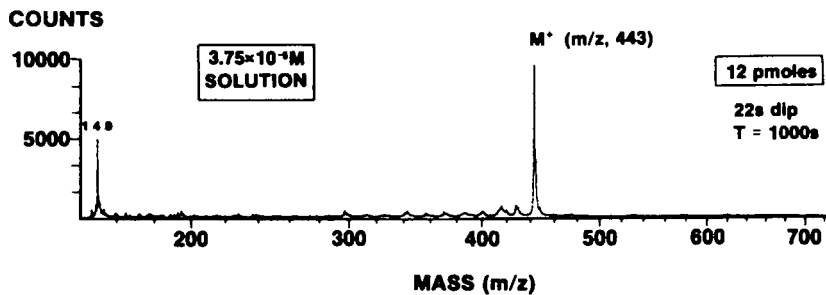


Figure 2: 252-Cf-PDMS spectrum of Rhodamine 6-G adsorbed from an ethanol solution onto Mylar.

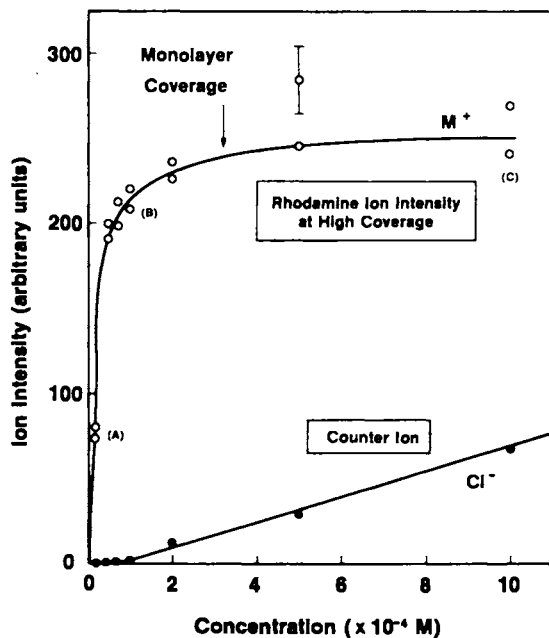


Figure 3: The molecular ion intensity of Rhodamine·6-G (determined by 252-Cf-PDMS) as a function of solution concentration.

low coverage but as an anion at high coverage. While there was no detectable change in the mass spectrum in the region of the molecular ion, there were significant differences in the dimer ion region. This is shown in Figure 4. At low coverage there is no evidence for dimer ion formation. At intermediate coverage, a broad distribution appears which is characteristic of metastable ion emission. This we attribute to the formation of contact pair dimers which are randomly aligned in the matrix. At high coverage where the solution contained a significant component of stable dimers there was a significant intensity of dimer-related ions in the mass spectrum. This first study confirmed the feasibility of carrying out mass measurements for a series of molecules with varying intermolecular separations.

Rhodamine-B. This molecule is closely related to Rhodamine 6-G in structure as well as in its optical properties. The 252-Cf-PDMS spectrum, however does have an important difference. It contains a fragment ion corresponding to loss of a carboxyl group. Since fragmentation is a measure of vibrational excitation within the molecule, it was possible to determine whether two Rhodamine-B molecules in close proximity behaved any differently from molecules isolated from each other on the surface. Figure 5 shows the results of this experiment. At low surface concentrations, the fragment and molecular ion intensity are comparable while at high coverage the fragment ion intensity is noticeably diminished. This observation suggests that the excitation energy can be shared amongst molecules when they are in close proximity. In a very recent measurement where the Rhodamine-B was adsorbed on an evaporated Au layer, the fragment ion was essentially absent. This indicates that the degree of molecular excitation can also be controlled by changing the substrate.

Emission of Massive Molecular Ions From Surfaces

Part of the current interest in the use of particle-induced emission for the mass spectrometry of organic species is that it has been possible to desorb ions of very large complex biomolecules like insulin. The current record is for the protein trypsin which has a molecular weight of 23,000 u (32). It is in the study of these species by the various particle-induced desorption methods that differences are beginning to appear between FAB, SIMS, and 252-Cf-PDMS. For the keV primary ion work (SIMS, FAB) differences are appearing that seem to be associated with the matrix. FAB has been more successful in producing these ions than SIMS. The reasons are not yet understood. It has been suggested by several investigators that the difference is associated with the higher mobility of solute species in the liquid matrix, but perhaps the liquid matrix is supporting the generation of an aerosol in the ion source or is providing a region of high local pressure where gas phase processes might occur. Benninghoven, earlier in the studies of molecular SIMS introduced the concept of a damage cross section to explain the observation that the yield of secondary ions decreases when the fraction of the surface not perturbed by the effects of the collision cascade diminishes (33). The suggestion was that the damaged area is actually depleted in molecules that could contribute to the desorption yield. The "damage cross section" is precisely a measure

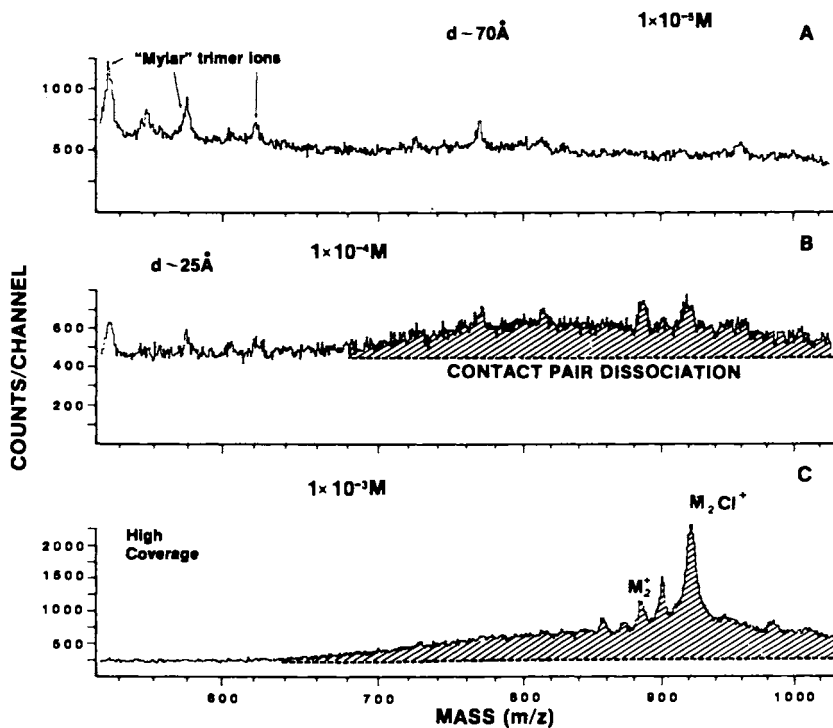


Figure 4: ^{252}Cf -PDMS spectrum of Rhodamine 6-G in the dimer region for various solution concentrations.

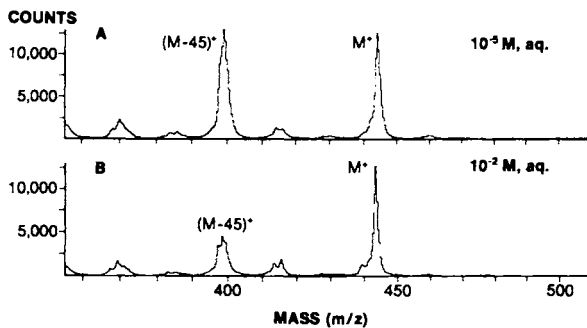


Figure 5: ^{252}Cf -PDMS spectrum of Rhodamine-B for films prepared from two different solution concentrations.

of the loss of the ability of the matrix to desorb species as ions and there may be several factors that could contribute to this effect. This is also observed for high energy ion excitation (34). The SIMS studies referred to earlier suggests that the damage regions represent parts of the matrix that have become amorphous (11). This means that when the molecules in the matrix become randomly oriented that part of the matrix cannot support the emission of molecular ions. For FAB however, the molecules in the excitation region only temporarily lose their relative alignment. Their high mobility in the fluid matrix gives them an opportunity to restore their preferred orientation which presumably enhances their intermolecular interactions. The implication here is that the formation of molecular ions may be mediated by the intermolecular interaction.

At the present, the FAB method has been able to produce molecular ions of biomolecules up to m/z 10,000 (35). Molecular ion yields are decreasing orders of magnitude with each 1000 u increase in mass. This is not the case for 252-Cf-PDMS. Other differences are beginning to show up. The average number of secondary ions emitted per incident ion is a factor of 4 higher for high energy primaries and multiplicities as high as 36 have been detected for some fission tracks (36,37). Sundqvist has shown that the desorption of large molecular ions requires the high energy density of the track produced by a high energy primary ion. The yield of insulin molecular ions varies as the LET to the sixth power while for small molecules the yield varies as the LET to the first or second power. This means that non-linear processes are involved in the desorption of these species. What these are is not known but it may be that the quenching processes observed in heavy ion tracks due to high concentrations of electron-hole pairs or molecular excitons may be contributing to the desorption of large, complex molecular ions. The LET of a typical SIMS primary ion is a factor of 10 lower than for a 252-Cf fission fragment. This translates to a six orders of magnitude enhancement for the yield of insulin for 252-Cf-PDMS relative to SIMS using a solid matrix. Processes occurring in the liquid matrix of FAB may enhance this yield.

The role of the matrix in the formation of molecular ions of large complex biomolecules seems to be more acute than with smaller molecules. It is hoped that the studies using adsorbed species on different surfaces will give insights to the optimum matrix for the desorption of these larger ions.

Conclusions

It is the intent of this Symposium to make some progress in the understanding of the similarities and differences of SIMS and FAB when these methods are used to produce molecular ions of biomolecules. Certainly some progress has been made in understanding some of the similarities in terms of the mode of primary energy transfer. Liquid matrix vs. solid matrix is a much more difficult question but the experimental facts at this time support the notion that the liquid matrix, under high primary flux excitation, has features that are not present in a solid state SIMS experiment. Where does 252-Cf-PDMS fit in this picture? Is it really SIMS and nothing more? Perhaps this is a question more philosophical than substantive at this point. The 252-Cf-PDMS method is a maverick in

the mass spectrometry community. None of its features fit into the mold of acceptable mass spectrometric methods but this is for us an attraction rather than deterrent. The historical perspective of mass spectrometry has a significant component of Darwinian evolution...the survival of the fittest ...of methods. The survival of 252-Cf-PDMS, or SIMS or FAB as a species for mass spectrometry of biomolecules will be dependent on their relative utility over a long time span; in 252-Cf-PDMS, time is a comfortable variable.

Acknowledgments

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Processes of Laser-Induced Ion Formation in Mass Spectrometry

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In its first part the paper discusses properties of laser desorption spectra of nonvolatile, fragile organic compounds as well as current models, suggested for the relevant ion formation processes. In the second part some recent results on metastable decay and the influence of the laser wavelength on desorption spectra are presented.

The generation of ions from solid samples by high power laser pulses has been intensely investigated in fusion research for over 20 years. The hot plasmas, produced in these experiments contain predominantly multiply charged ions of high kinetic energy (33). The generation of ions out of the condensed phase with lasers for analytical purposes in mass spectrometry has only more recently gained considerable interest. Three fields of application justify this interest:

1. Laser beams can be focused down to the diffraction limit of 0.2 - 0.5 μm with very high efficiency. This has led to the development of the Laser-Mass-Spectrometric Microprobes LAMMA 500^R, LAMMA 1000^R and LIMA. These instruments are designed for tasks in principle comparable to those of dynamic SIMS or imaging ion-microprobes.
2. A convincing body of experimental information, now available in the literature, serves as confirmation for the possibility to desorb molecular ions out of the condensed phase even for organic molecules which are generally considered nonvolatile and/or fragile and do therefore not lend themselves to classical mass spectrometric analysis. Here the laser-MS competes with techniques such as static SIMS or FABMS, plasma- and field-desorption.
3. At suitably high laser irradiances at the solid surface, a plasma is formed as mentioned above. With properly chosen irradiation parameters, this plasma shows features, comparable to those of HF-spark sources, commonly used in mass spectrometry of inorganic solid samples. From results, reported in the literature (1, 2, 3), it can be deduced that the laser source may offer some advantages over classical spark sources with respect to sample preparation (nonconductors), reproducibility, collection efficiency and uniformity of elemental sensitivity factors. The laser in addition

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offers the advantage of high spatial resolution as described in 1.

The results reported by the different groups have all been obtained with experimental arrangements that differ greatly in the types of laser used, the wavelengths, time regime and irradiances on the sample, in the sample geometry and sample preparation, the mass spectrometers and the detection systems. The most pertinent information on the different systems that have been successfully applied to organic mass spectrometry is compiled in ref. (4).

This paper contains a discussion of the most important features of laser-induced-ion spectra and mechanisms of ion formation, some of them experimentally proven, some of them still under discussion and investigation. Special attention will be given to the LAMMA technique, because this is the authors own field of work, but reference to other systems will be included where appropriate.

Characteristics of spectra

Ion spectra of inorganic as well as of organic samples have been published by many authors. Typically they exhibit the following general features:

1. Within the useful range of experimental parameters, almost exclusively singly charged ions are detected.
2. To a higher or lesser degree - depending on the experimental technique - ion initial energy distributions do not reflect equilibrium distributions and attempts to fit them to a Maxwellian distribution leads to temperatures that are too high to be realistic.
3. Ions of both polarities are generated, usually at comparable abundances. For atomic ions, their yield is governed in first order by the ionization potential or electron affinity. For acidic compounds, specific molecular ions (e.g. $(M-H)^+$) are found mostly in the negative ion spectra; for basic compounds specific ions (e.g. $(M+H)^+$, $(M+Alkali)^+$) are more easily identified in the positive ion spectra. The somewhat surprising results obtained for organic salts will be discussed further down.
4. Relative sensitivity factors for atomic ions out of a given matrix vary by only one, in extreme cases by about two, orders of magnitude at least for the high irradiance techniques (1). This holds even for ions of only one polarity, i.e. under suitable conditions ions such as F^- or Cl^- are detected in positive ion spectra. This contrasts favourably with e.g. SIMS where sensitivity factors vary by several orders of magnitude.
5. The spectra of both atomic and molecular ions are qualitatively and quantitatively influenced by the surrounding matrix and the bonding state of a given species to that matrix. Again this influence becomes less pronounced in the detection of atomic ions at higher irradiances.
6. Cluster ions such as Me^+ (5) for metals, MeO_x^+ (6, 7) from binary metal oxides and AH_x^+ (8) for alkali halides, unspecific $C_nH_m^+$ clusters as well as specific $(2M+Na)^+$ (9) for organic molecules are relatively frequent up to relative cluster masses of several hundred. Cluster distributions reflect bond energies and cluster stabilities, but they cannot usually be fitted by a distribution

function reflecting a realistic equilibrium temperature (8). Cluster distributions seem to drastically depend on the sample preparation technique and the surface state.

For molecular ions some additional features are observed:

7. Polarity of the molecule seems to be supportive to desorption in contrast to thermal evaporation, where polar groups must, as a rule, be derivatized, to render a molecule volatile.
8. Ions are predominantly of the even electron type, protonation and deprotonation rather than electron abstraction or attachment are common processes. Radical ions are only rarely generated from strongly aromatic compounds (see Fig. 7).
9. Cationization by alkali-metal ions is very frequent. Cationization by other metal ions (e.g. Ag, Cu, Mg etc.) has also been observed under suitable conditions (10, 11, 12) as has been anionization; e.g. by chlorine (11).
10. For the techniques using very short, high irradiance laser pulses, a more or less smooth transition to pyrolysis of the sample is observed with increasing irradiance. It appears that at least for the LAMMA technique this transition does not always occur at identical irradiances for positive and negative ions. This will be discussed in more detail later in this paper.

At least for molecular ions, the similarities between all desorption spectra are believed to result from common chemistry that the molecules or ions undergo. It appears that in all desorption techniques there must be a step at which such chemical reactions can occur, most probably as a stabilizing step. Most of this chemistry seems to be governed by much the same molecular properties that are also known to govern most of the chemistry in the gas phase or in solution. It is then obvious that these common features must not necessarily indicate equal excitation and ion formation processes for all the desorption techniques or even among the different laser desorption arrangements. Indeed, the rather different mechanisms, discussed in the following section, have only rather recently been recognized, and only after the more subtle differences in the spectra and other ion properties had been worked out.

Ion formation mechanisms

Four ion formation processes can at least in principle be distinguished. They contribute to varying degrees to the spectra obtained with the different techniques

1. Thermal evaporation of ions from the solid.
2. Thermal evaporation of neutral molecules from the solid followed by ionization in the gas phase.
3. Laser desorption.
4. Ion formation in a laser generated plasma.

The first two processes are called thermal, because they can also be induced by classical Joule- or non-laser radiative heating, usually in conjunction with heat conduction to the sample surface. Thermal evaporation of cations of quaternary ammonium salts and anions of sodium tetraphenylborate has been demonstrated by several groups (13, 14, 15). Such a thermal evaporation of ions, common for metals and inorganic salts such as alkali halides, had not originally been expected to occur for organics as well. It should be most pro-

bable for organic salts with quarternary salts possibly exhibiting a singularly high yield (13).

Volatility, together with thermal stability are the two terms that are used to characterize the chance for thermally evaporating neutral molecules from the condensed into the gas phase. Based on former experiments employing mostly electron ionization, most organic molecules, particularly bioorganic ones with relative molecular masses above about 100 were believed to be involatile and thermally unstable. Recently Röllgen et.al. (14, 15, 16, 17) as well as Kistemaker et.al. (18, 19, 20) have published investigations that strongly point to a thermal evaporation of neutral molecules of sucrose and a number of other organic substances followed by ionization in the gas phase by ion-molecule reactions with alkali ions. If no separate source for the alkali ions is provided, the existence of separate areas of lower temperature, just high enough for the onset of evaporation of intact neutral molecules (e.g. ~ 300 - 350°C), and of high enough temperature (> 750°C) for thermal evaporation of alkali ions are a prerequisite for this process to occur. In all likelihood, this is the dominating ion formation process in all the CW-CO₂-laser experiments. Besides ion-molecule reactions in the gas phase, thermal surface ionization at hot surface areas presumably through decomposition of neutrally evaporated clusters of salts of carboxylic- and sulfonic acids has also been suggested (14). COTTER et.al. (22, 23, 24) have in addition shown that the evaporation of ions and even more of neutrals may persist for times of 10-20 μs, considerably beyond the laser exposure, if temperature decay is slow. This is because of the amount of energy deposited and because of limited heat conduction. In the experiments, pulsed CO₂-laser (~ 100 ns) with irradiances around 10⁶ W/cm² have been used. Thermal equilibrium should certainly be established on the molecular scale in this time domain, yet molecular ions of relative mass beyond several thousand have been observed with peak temperatures, calculated by the authors, of ca. 2000K.

These results certainly call for future extensive and systematic investigations of the volatility of organic molecules and ions as a function of molecular size and structure. There seems to be some evidence that neutral peptides up to $M_r/Z < 1900$ can be evaporated by slow radiative heating of samples on a gold substrate (25). In view of these observations, the frequent statement that polarity generally supports "desorption" may also need further consideration, at least in cases where thermal evaporation plays a key role in the ion formation.

The term desorption is used in contrast to evaporation in cases in which a transition of a molecular or ion from the condensed into the gas phase is assumed to take place under non thermal equilibrium condition. The underlying idea is that at thermal equilibrium, temperatures for an evaporation would lead to a correspondingly high excitation of internal vibrational modes of excitation leading to fragmentation of the molecule. As mentioned above, several characteristics of the ion spectra (2., 6.) cannot reasonably be fitted to an equilibrium temperature model. These properties seem to be the more pronounced, the higher the laser irradiance (i.e. usually the shorter the pulse) and are best documented for the LAMMA technique. Though metastable decay of ions is observed and will be discussed below, the decay rate for most of the ions is very small and decay

times are long. In particular, peak widths of spectra obtained with the ion reflector. i.e. with instruments that compensate for the initial energy distribution, reflect ion generation times of at most 10 ns, i.e. within the laser pulse length. This indicates no appreciable ion decay or gas phase reactions during the ion acceleration phase; i.e. in the time range of ten to several hundred nanoseconds at distances beyond ca. 10 μm from the sample surface.

The mechanisms that lead to such laser desorption are now believed to be collective, non equilibrium processes in the condensed phase (26). In this respect they are closer to processes that must be assumed to lead to ion generation in SIMS and plasma desorption rather than to the thermal laser induced ion generation discussed above, even though the spectra are often indistinguishable for all different laser techniques. The recently reported observation of metal ion (Cu, Ag, Mg etc.) attachment for desorption with high power, short pulse lasers (10, 11, 12) also points to the similarity with SIMS.

The reason for the dominance of such desorption processes vs. thermal evaporation is most easily understood for the LAMMA 500^R arrangement. Because of the tight focusing of the laser beam, the total energy delivered is typically only about 100 nJ or less. Moreover, there is no substrate that could absorb energy and then conduct it to the sample; both sample and thin-film-substrate are usually "evaporated" simultaneously in the focus during the laser shot. The total affected volume of about $< 0.1 \mu\text{m}^3$ expands at a speed of 10^5 cm s^{-1} or more. As a result, probability of gas phase collisions for a given ion or molecule is very small compared to arrangements with large irradiated areas and/or long irradiation times. Thermal processes are much more likely for the LAMMA 1000^R arrangement. FEIGL et.al. (27) were able to show that at ion generation threshold ($\sim 0.1 \mu\text{J}$) from a bulk metal surface, ion generation occurs essentially during the laser pulse time only. At 10-times threshold energy ($\sim 1 \mu\text{J}$), the strong ion emission during laser irradiation is followed by a emission of ions lasting for several microseconds, presumably of thermal origin due to the heated bulk sample. This is in agreement with the above discussed results reported by Cotter.

The details of the formation processes of the observed ions are as yet not well understood. The frequent observation of ions which have undergone substantial structural rearrangements or even chemical reactions, unlikely to occur on a nanosecond timescale in the solid state, suggest that there is an intermediate state of higher mobility, similar to suggestions made for SIMS. The upper limits given above for times and locations within which such reactions would have to take place would certainly allow such an intermediate state to have particle densities several orders of magnitude below that of solid state density. Yet average particle distances and the lack of a shielding solvent probably prohibit a direct application of liquid- or gas phase chemistry to this intermediate state, particularly as it is of transient nature, such that no chemical and probably even no thermal equilibrium is attained.

At laser irradiances of typically about $10^{10} \text{ W cm}^{-2}$ and above, dense plasmas are formed from any solid sample, as is well documented by the large number of laser fusion experiments. In this mode of operation, energy is deposited into the solid during the initial

phase of the laser pulse only, creating a highly absorbing plasma in front of the surface, shielding it from incoming radiation of the later part of the laser pulse (28). A substantial amount of energy of the laser beam will thereby be deposited into the plasma, increasing its temperature as well as density of ions and electrons. The plasma mode is certainly not suited for organic mass spectrometry. Molecules will be mostly broken down to their atomic constituents, multiply charged atomic ions will become abundant with increasing laser irradiance and ion initial energies will extend into the range of kilo-electronvolts. For the analysis of inorganic specimen such as metals or minerals, this mode has on the other hand been shown to have decided advantages, because the ion yields become nearly uniform for all elements throughout the periodic table (1, 2, 3). It remains puzzling though that even under operational conditions at which the formation of relatively dense plasmas in local thermodynamic equilibria is expected, abundance of doubly charged ions is usually below the detection limit. This would imply a strong recombination probability prior to acceleration of the ions. Though there seems to be sufficient experimental evidence for the four mechanisms discussed to be active in the various laser desorption experiments, the actual interpretation of experimental results may not be as straightforward. In many cases, more than just one process may contribute to the results observed. For example, it is quite likely that under a suitable choice of experimental parameters in laser desorption with high power lasers, one can simultaneously create a plasma in the center of the non uniformly irradiated area, get laser desorption from the periphery and even thermal emission due to a heated substrate for times longer than the laser pulse.

Discussion

From the above discussion of the characteristics of the spectra and ion formation mechanisms, it is obvious that, though there can be no doubt about the usefulness of laser mass spectrometry for a large variety of analytical tasks, more research is needed for a better understanding. This is particularly true for the transition from thermal evaporation to desorption and the desorption mode itself. In the following, a few first results of such experiments, conducted recently in the author's group, will be reported.

Wavelength dependence of ion formation

Laser wavelength should be one of the key parameters in systematic investigations into ion formation processes. Results should be particularly indicative for bioorganic molecules and wavelengths in the far UV, where strong differences in classical absorption for different groups of such molecules are known to exist. The group at the institute of spectroscopy of the USSR Academy of Sciences has reported strong resonance desorption in the far UV for a number of molecular systems (29, 30, 31). On the other hand, the above mentioned collective, non equilibrium processes do not suggest a direct influence of classical resonance absorption for irradiances above about 10^7 W/cm², at which all samples very effectively absorb energy from the radiation field. Nevertheless, the spectra shown in Fig. 1 seem to de-

monstrate such resonance effects at irradiances close to ion detection threshold. For the wavelength of 266 nm, tyrosine exhibits strong, serine almost no classical absorption. At threshold irradiance, the tyrosine spectrum (top right) shows the parent molecular ion as the base peak with only two other contributions by the decarboxylated molecule and the molecular residue. In particular, no signals of alkali-ions or alkali-attached ions are detected. These ions appear only at irradiance a factor 2 above threshold (lower right). At the same time, the contributions of the fragment-ions increase considerably apparently at the cost of those of the parent molecule. Ion detection for the non absorbing serine occurs only at an irradiance another factor of 3 higher (lower left). Even at threshold strong contributions from alkali ions and alkali-attached molecular ions are always observed, as well as cluster ions. Very similar results have been obtained for other pairs of aromatic and aliphatic aminoacids as well as for small peptides containing only aliphatic aminoacids or those of both types. These experiments will be pursued in more detail in the future.

Formation of metastable ions

As discussed above, metastable decay should, among others, yield information about the degree of internal excitation of the generated ions. A LAMMA 500ⁿ instrument has therefore been supplemented to allow for the simultaneous detection of ions and neutrals (Fig. 2). With the potentials of the various sections of the instrument set as shown, the detector in the ion-reflected path will register all ions at their respective mass numbers that remained stable during the whole acceleration- and flight time ($\sim 20 \text{ ns} \leq t < \sim 50 \text{ }\mu\text{s}$ for ions of $M_r/Z = 500$). Due to the geometry of the reflector, ions created by metastable decay along all of the flight path will usually not reach the detector. Neutrals, formed by decay during the ion flight time in the drift region preceding the ion reflector ($\sim 200 \text{ ns} < t < \sim 25 \text{ }\mu\text{s}$ for parent ions of $M_r/Z = 500$), will be registered by the second, straight tube detector. It should be noted that these neutrals are recorded at the massnumber of their parent ion, rather than their true mass. With this arrangement, the generation of neutrals through metastable decay and some features of the spectra of positive- vs. those of negative ions out of some organic acids and their salts have been studied.

Figs. 3 and 4 show the positive and negative ion spectra of phthalic acid (up) and their neutrals (down). All major peaks of the spectra of either polarity can be assigned to the parent molecule or to relatively simple fragments. Metastable decay is somewhat more pronounced for the negative ions. It should be noted that the two detection paths have not, so far, been absolutely calibrated relative to each other, so the spectra of ions and neutrals cannot be compared on an absolute scale. The spectra of positive and negative ions of the salt sodium phthalate are shown in Figs. 5 and 6. Though taken at comparable laser irradiances among each other and to those of the acid, the spectra are quite different from those of the acid. Most of the major peaks in the positive ion spectra can again be assigned to the parent molecule or simple fragments thereof, but metastable decay is considerably more pronounced. The negative ion spectrum is different

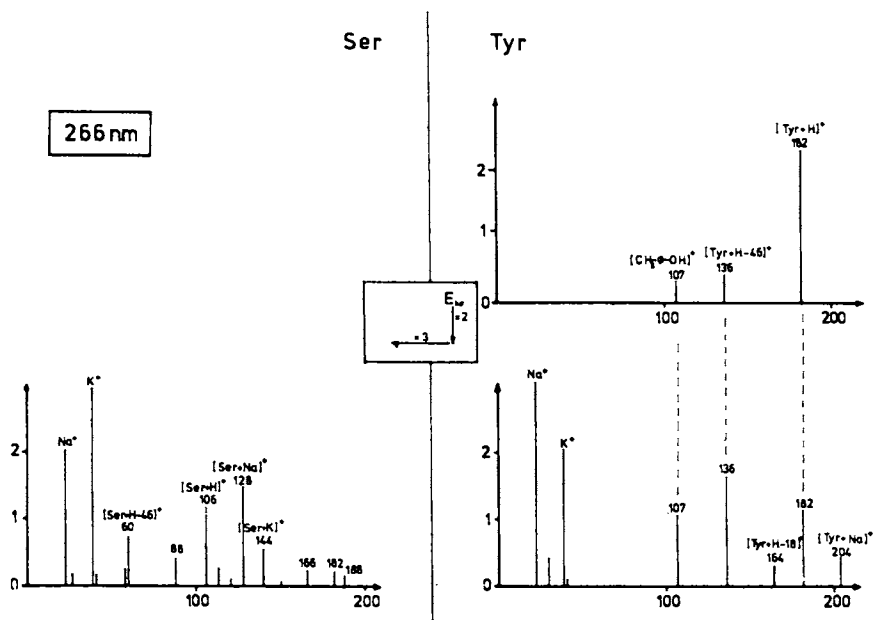


Figure 1. Spectra of the aminoacids tyrosine (Tyr) and serine (Ser), obtained at different laser irradiances $E_{lh\nu}$. Laser wavelength was 266 nm. For explanation see text.

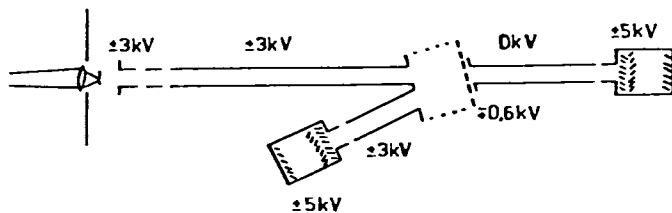


Figure 2. Schematic diagram of LAMMA 500 instrument, adapted for simultaneous detection of ions and neutrals.

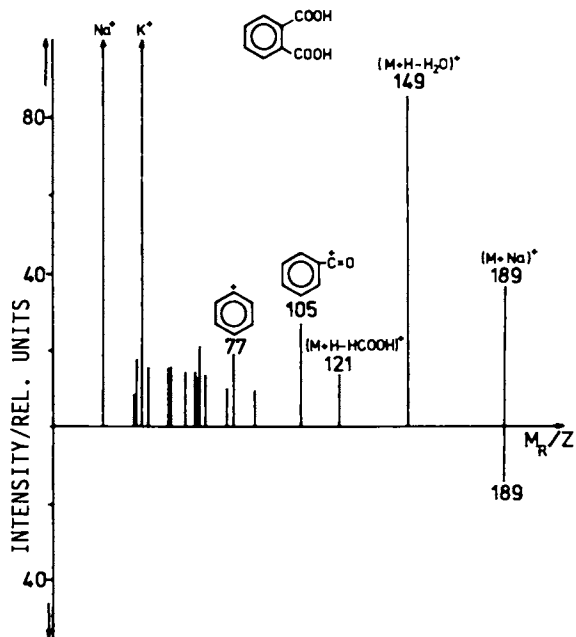


Figure 3. Positive ion spectra (up) of phthalic acid and of neutrals (down) from metastable decay of positive ions.

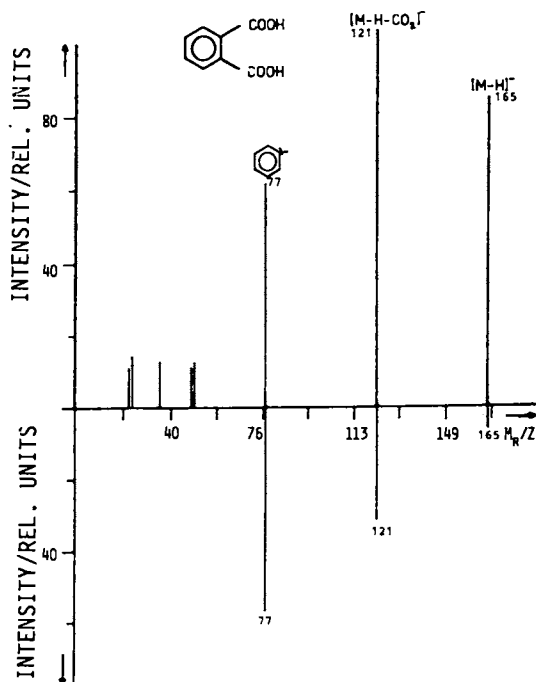


Figure 4. Negative ion (up) spectra of phthalic acid and of neutrals (down) from metastable decay of negative ions.

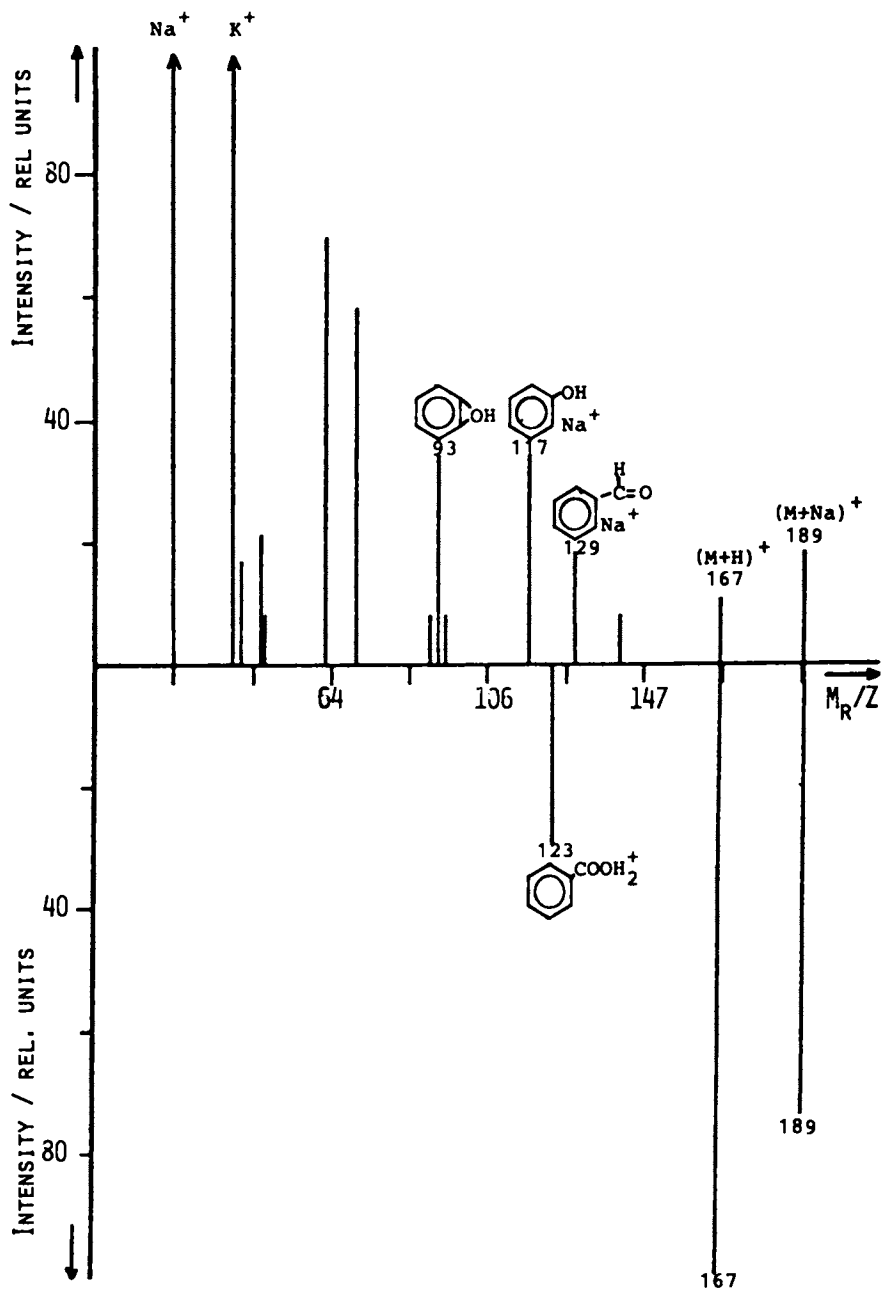


Figure 5. Positive ion (up) spectra of sodiumphthalate and of neutrals (down) from metastable decay of positive ions.

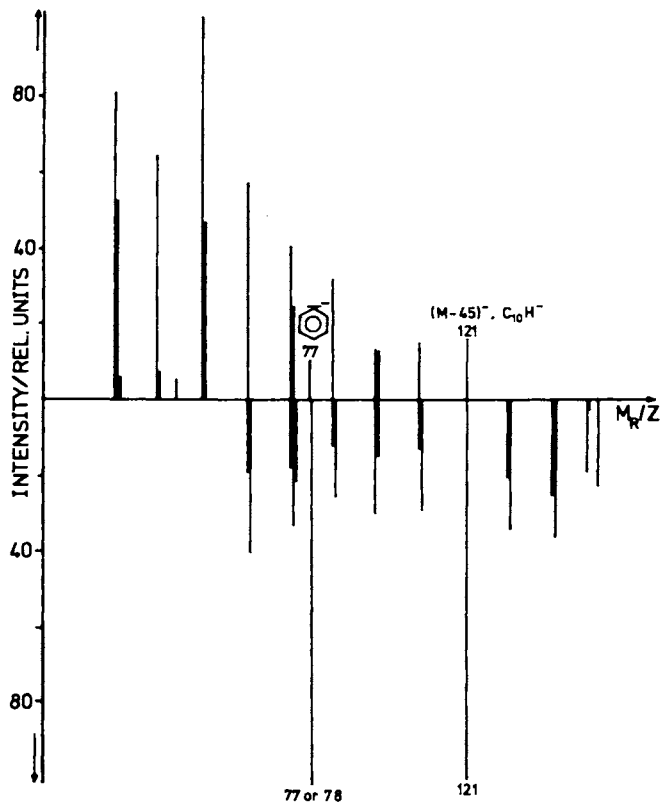


Figure 6. Negative ion (up) spectra of sodiumphthalate and of neutrals (down) from metastable decay of negative ions. All non assigned peaks represent C_nH_m cluster ions.

altogether. Only the small peak at $M_r/Z = 77$ can unambiguously be assigned to a fragment of the parent molecule; the peak at $M_r/Z = 121$ may contain a contribution from the decarboxylated parent anion, as evidenced by the very strong peak of neutrals. All other ion- and neutral signals represent unspecific C_nH_m -clusters. It is interesting to note further that the centroid of the cluster distribution of the neutrals as compared to the ions is strongly shifted towards larger clusters.

A considerable difference between the spectra of positive and negative ions is also typical for highly aromatic compounds. Fig. 7 shows the spectra of benzopyrene as an example. The positive ion spectrum is amazingly simple. Detection of the radical parent ion is

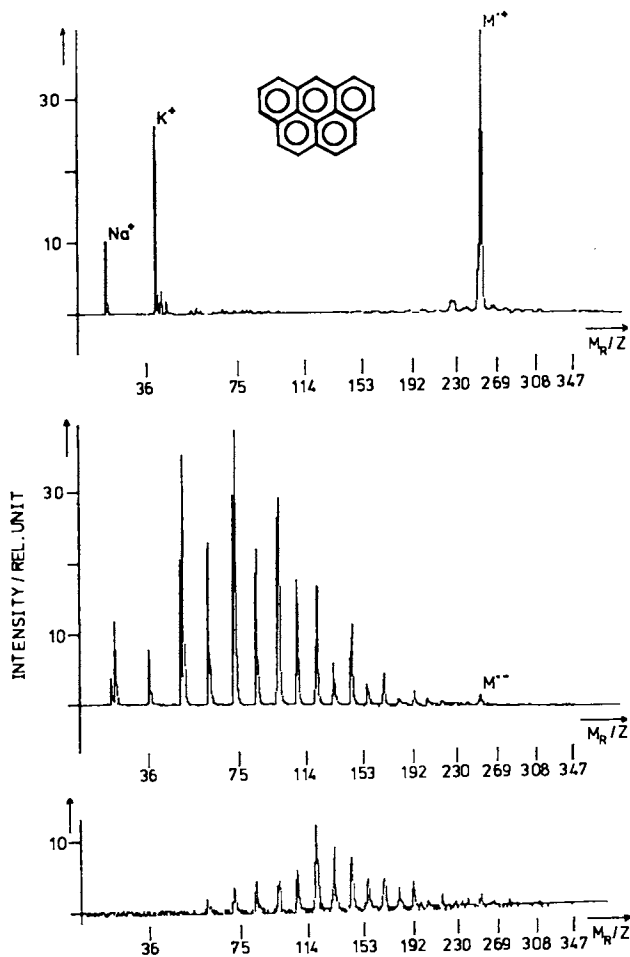


Figure 7. Positive- (top) and negative ion (middle) spectra and of neutrals (bottom) from metastable decay of negative ions of benzopyrene.

typical for highly aromatic compounds. No neutrals from positive ion decay have been detected. The negative ion spectrum and that of their neutrals on the other hand resemble very much those of the salt shown before. Similar observations as to the differences between positive- and negative ion spectra have also been made by other investigators (32). At this stage of the investigation, we suspect that the phenomenon is observed only for samples, which, upon laser irradiation, generate a substantial number of electrons besides ions and neutrals. In the negative ion mode, these electrons are accelerated along with the ions, resulting in collisions and electron attachment.

The described experiments will have to be continued and other, and more sophisticated experiments need to be designed in order to unravel at least the most important basic processes in laser desorption. Hopefully a better understanding of these processes will then lead to an optimization of the instrumental parameters for a given analysis.

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Angle-Resolved Secondary Ion Mass Spectrometry

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The interaction of keV particles with solids has been characterized by the measurement of the angle and energy distribution of sputtered secondary ions and neutrals. The results are compared to classical dynamics calculations of the ion impact event. Examples using secondary ions are given for clean Ni(001), Cu(001) reacted with O₂, Ni(001) and Ni(7 9 11) reacted with CO, and Ag(111) reacted with benzene. The neutral Rh atoms desorbed from Rh(001) are characterized by multiphoton resonance ionization of these atoms after they have left the surface.

The collision of a keV heavy particle with a solid initiates a complex series of events which may ultimately lead to the ejection of a variety of atomic and molecular species. The composition of these species are often characteristic of the original make-up of the target. Whether dealing with a low dose SIMS experiment or a focussed primary beam used for ion microscopy, it is necessary to obtain a detailed understanding of the ion bombardment event to appreciate the mechanisms involved in the ejection process. In a global sense, there are two phenomena which need to be examined. The first is to predict the nuclear motion in the solid which gives rise to the ejection of atoms and the second is to evaluate the inelastic events that give rise to excited species and secondary ions. The first aspect of the problem has been extensively developed utilizing a straightforward classical dynamics model to follow the flow of energy through the lattice for the first picosecond or so after bombardment.⁽¹⁾ The ionization problem is much more difficult, although progress is now being made using a number of approaches.

It is our view that in order to compare experimental measurements to the emerging theoretical predictions, it is

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necessary to be very careful in specifying the type of sample to be studied and in defining the measurement conditions as precisely as possible.

In this paper, we report on a series of experiments aimed at measuring the yield of secondary ions and neutrals as a function of their take-off angle and their kinetic energy. This approach, rather than measuring angle and energy-integrated yields, allows much more detailed comparisons to theory and makes the testing of proposed models much more straightforward.

Angular Distributions of Secondary Ions From Clean Single Crystal Surfaces

Using the general experimental and theoretical approach described above, it is now our goal to see what type of structure-sensitive information exists in the angular distributions of the secondary pions. As Wehner showed many years ago, the distributions of the neutrals are highly anisotropic and very clearly reflect the surface symmetry. There have been many attempts to explain these distributions. One such explanation is that the ejection occurs along close-packed lattice directions which extend deep within the crystal.(2) This idea nicely explained the peaks in the angular distributions but required that there be quite a bit of long range order in the solid even during the impact event. That requirement seems a bit hard to swallow in view of the extensive damage that is created within the crystal. Although controversy existed concerning these "focusons" for many years, the molecular dynamics calculations of Harrison clearly showed that the ejection was dominated by near surface collisions rather than those from beneath the surface.(3)

Ni⁺ Ion Angular distributions from Ni{001}. The results of calculations are displayed schematically in Figure 1, where a Ni{001} crystal face is given as an example. Here, each atom's ultimate fate is plotted as a point on a plate high above the solid. Atoms that are ejected perpendicular to the surface ($\theta = 0^\circ$) are plotted in the center of the plate.

The molecular dynamics calculations yield a clear picture of the scattering mechanisms that give rise to these angular anisotropies, particularly for the higher kinetic energy atoms. Most of the ejected particles arise from within two or three lattice spacings from the impact point and suffer only a few scattering events. The spacings between the surface atoms exert a strong directional effect during ejection. Note that most particles are ejected along $\phi = 0^\circ$, since there are no atoms in the surface to block their path. The nearest neighbor atom along $\phi = 45^\circ$ inhibits ejection in this direction. It is possible, using the apparatus shown in Figure 2, to compare the measured angular distributions of secondary ions to the calculated distributions for a clean Ni{001} single crystal surface.(4) The results of this comparison are shown in Figure 3.(5) Each panel represents an azimuthal angle scan at a particular polar angle. The calculated curves have been corrected for the presence of an image force which tends to bend the secondary ions toward the surface plane. The agreement between the two curves is reasonable under all

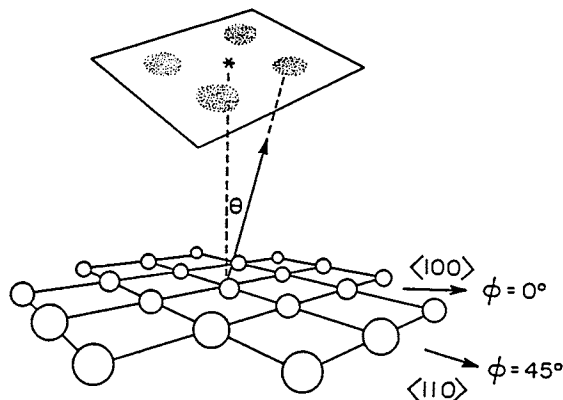


Figure 1. Coordinate system used in determining angular distributions.

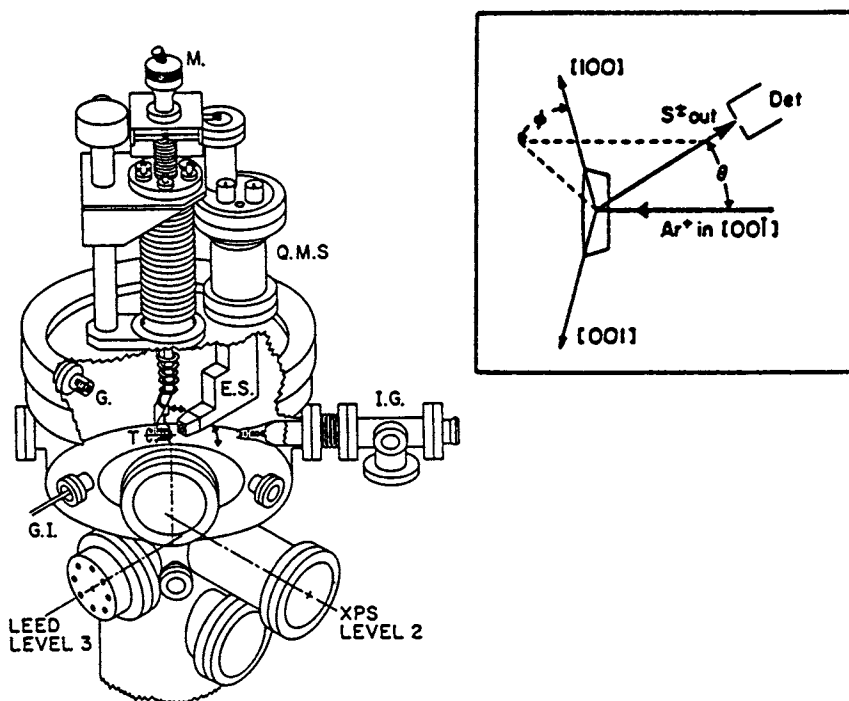


Figure 2. Schematic view of the spectrometer. The components illustrated include M, crystal manipulator; Q.M.S., quadrupole mass spectrometer; I.G., primary ion source; E.S., energy spectrometer; G, Bayard-Alpert gauge; T, crystal target; and G.I., gas inlet. Auxiliary components are omitted for graphical clarity. The SIMS experimental geometry and coordinate systems are defined in the inset. Reproduced with permission from Ref. 4. Copyright 1981, American Institute of Physics.

conditions. Note that in accord with the schematic presentation in Figure 1, the secondary ion intensity maximizes at $\phi = 0^\circ$ and minimizes at $\phi = 45^\circ$ for $\theta > 45^\circ$. Thus it appears that in this simple situation, ion angular distributions behave similarly to the neutrals and are well-predicted by theory.

Ni₂⁺ Ion Angular Distributions from Ni{001}. A real advantage of the static SIMS method over other surfaces analysis techniques is that molecular cluster ions may be produced which are characteristic of the surface chemistry. It would be most interesting, then, to be able to obtain the angular distribution of these species to see if they too contain information about surface structure. As shown in Figure 4, the experimental angular distributions for Ni₂⁺ ions actually exhibit a sharper azimuthal anisotropy than the Ni⁺ ions.(5) This result is also observed in the classical dynamics calculations.(6) Of particular interest in this case is the fact that the mechanisms that give rise to this increased anisotropy can be ascertained from the theory. As it turns out, most of the dimers that are formed at $\phi = 0^\circ$ and $\theta = 45^\circ$ originate from a similar set of collision sequences as illustrated in Figure 5. The Ar⁺ ion strikes target surface atom 4, initiating motion in the solid that eventually ejects atoms 1 and 3 into the vacuum. Both of these atoms are channeled through the fourfold holes in the $\phi = 0^\circ$ direction, are moving parallel to each other, and are fairly close together. Note that the two atoms that form the dimer do not originate from nearest-neighbor sites on the surface.

There is an important ramification of the concept that the dimers that give rise to the maxima in the angular distribution are formed primarily from constituent atoms whose original relative location on the surface is known. If this result were extrapolated to alloy surfaces such as Ni₃Fe(111), the relative placement of the alloy components on the surface would be determined. For example, for the Ni₃Fe(111) spectra there should be no nearest neighbor Fe atoms on a perfect (111) alloy surface, yet an Fe₂⁺ peak is observed.(7)

Angular Distributions of Secondary Ions From Adsorbate Covered Surfaces

The channeling phenomena observed from clean surfaces should also be found in more complex systems such as metals covered with a chemisorbed layer. For these cases, there are various ways in which one might envision the angle to be important. Examples of azimuthal anisotropies have already been seen for the case of clean metals where surface channeling and blocking give rise to the observed effect. This situation should also apply to adsorbate covered surfaces. Other possibilities include the study of anisotropies in the polar angle distributions as well as in the yield of particles due to changes in the angle of incidence of the primary ion.

Considerable progress in quantitatively describing the ejection of chemisorbed atoms and molecules from metals has been made using molecular dynamics calculations. The main difficulty in describing any situation like this is to develop appropriate interaction potentials which describe the

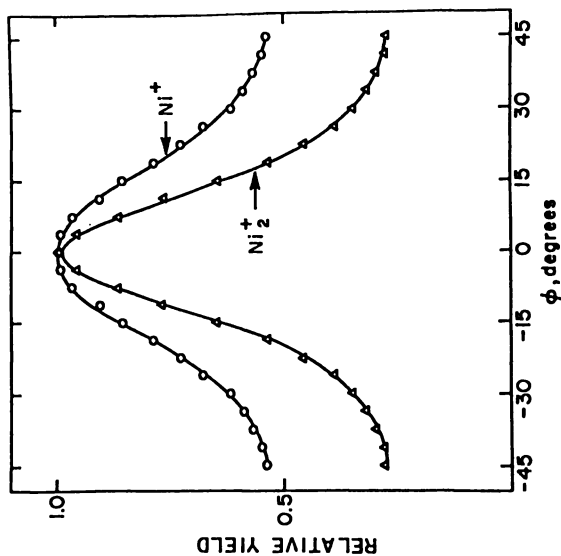


Figure 4. Experimental angular distributions of Ni^+ and Ni_2^+ ejected from $\text{Ni}(001)$ at a polar angle of $45 \pm 5^\circ$. The center-of-mass kinetic energy of the particles is between 10 and 50 eV. Both curves are fourfold averages of the kinetic energy and is at normal incidence. The solid is at room temperature. The peak counts are ≈ 900 and ≈ 500 counts/sec for the Ni^+ and Ni_2^+ distributions, respectively. The $\langle 100 \rangle$ azimuthal directions correspond to $\phi = 0^\circ$. Reproduced with permission from Ref. 6. Copyright 1980, American Physical Institute.

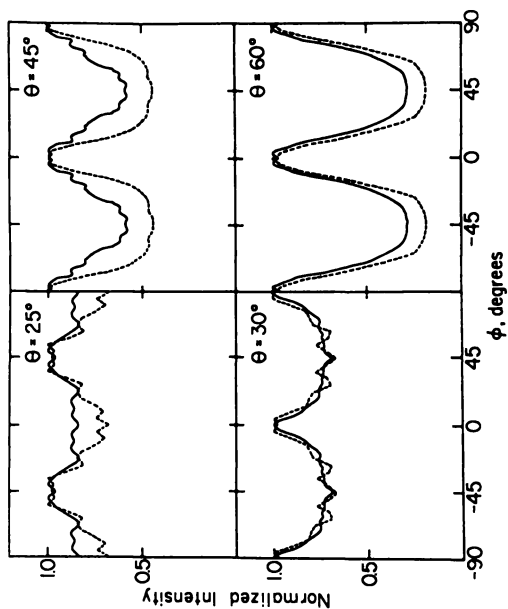


Figure 3. Dependence of Ni^+ ion yield on azimuthal angle at various polar angle for clean $\text{Ni}(001)$ bombarded by 1500 eV Ar^+ ions at normal incidence. The solid curves represent experimental data while the dashed curves are predicted values obtained by $^+$ ion bombardment for the calculated yields for 1000 eV Ar^+ ion correcting for the presence of the image force. Only those particles with a kinetic energy of 4 ± 4 eV were detected. Reproduced with permission from Ref. 5. Copyright 1982, American Institute of Physics.

scattering events. Since little is known about these potentials, early calculations have utilized pair-wise additive potentials for adsorbates which have the same form as for the substrate, but with different mass. The exact form of the potential is not as critical as the atomic placement of the adsorbate atom. Thus, in the calculation, the geometry and coverage of the adsorbate may be varied over a wide range to test how these quantities influence ejection mechanisms and ultimately the angular distributions. In this section, examples of how several different experimental configurations can be utilized will be reviewed.

Atomic Adsorbate. The first application of angle-resolved SIMS to the determination of the surface structure of chemisorbed layers is for oxygen adsorbed on the {001} face of Cu.(6) In this situation, the oxygen overlayer forms a c(2x2) structure as determined by LEED. Classical dynamics calculations indicate that the oxygen should be ejected in the $\phi = 0^\circ$ direction if it is originally bonded above the copper atom, because it is directly in the path of the ejected substrate species. However, if the oxygen is in a hole site, bonded to four substrate atoms, its predicted angle of ejection is $\phi = 45^\circ$. Experimental studies have confirmed that the oxygen resides in a fourfold bridge site because it is ejected in the $\phi = 45^\circ$ direction.(6)

There are a number of complications associated with this simple interpretation. First, the magnitude of the azimuthal anisotropies are dependent upon the kinetic energy of the desorbing ion. For the very low energy particles, there has been sufficient damage to the crystal structure near the impact point of the primary ion that the channeling mechanisms are no longer operative. On the other hand, at higher kinetic energies, say greater than 10 eV, the desorbing ion leaves the surface early in the collision cascade while there is still considerable order in the crystal. The channeling mechanisms are much stronger and the angular anisotropies are larger.

A second complication involves the determination of the height of the adsorbate atom above the surface plane. Calculations have been performed where this bond distance has been varied over several angstroms in order to find the best fit with experiment.(8,9) These studies have also shown that there is a sensitivity of the polar angle distribution to the effective size of the adsorbed atom. Thus, it is important to know more about the scattering potential parameters if this distance is to be determined accurately. It appears, however, that the type of adsorption site may be determined in a reasonably straightforward manner.

Adsorption of CO on Ni{001}. The response of a surface to ion bombardment covered with a molecularly adsorbed species is mechanistically distinct from the atomic adsorbate case. For CO on Ni{001}, for example, the strong C-O bond of 11.1 eV and the weak Ni-CO bond of 1.3 eV allows the CO molecule to leave the surface without fragmentation. In the experimental studies, the main peaks in the SIMS spectra for a Ni{001} surface exposed to a saturation coverage of CO are Ni^+ , Ni_2^+ , Ni_3^+ , NiCO^+ , Ni_2CO^+ , and Ni_3CO^+ . All

ions show a smooth increase in intensity with CO adsorption and reach saturation after 2-L CO exposure (0.5 monolayer coverage). The yields of C^+ , O^+ , NiC^+ and NiO^+ , are all less than 0.01 of the Ni^+ intensity.

The classical dynamics treatment for CO on Ni(001) yields results which are in qualitative agreement with these findings. Approximately 80% of the CO molecules that eject are found to eject intact, without rearrangement. The formation of NiCO and Ni_2CO clusters have been observed to form over the surface via reactions of Ni atoms and CO molecules. No evidence has been found for NiC and NiO clusters in the calculations. The ion bombardment approach, then, is a very sensitive probe for distinguishing between molecular and dissociative adsorption processes.

A number of workers have attempted to identify structural relationships found using other techniques such as LEED and vibrational spectroscopy to cluster yields in SIMS. The correlation of Ni_2CO^+ to bridge-bonded CO and $NiCO^+$ to linear bonded CO is an example of this approach. As it happens, the calculations clearly show that the mechanism of cluster formation is not consistent with this picture since the clusters form over the surface via atomic collisions. Furthermore, combined LEED/SIMS results indicate that the cluster ion yields are not directly related to the adsorbate/substrate geometry.⁽¹⁰⁾ The c(2x2) structure of CO on Ni(001) with all the molecules in the atop site gave the same $Ni_2CO^+/NiCO^+$ ratio as the compressed hexagonal LEED structure which must have both A-top and bridge-bonded CO molecules.

On the other hand, it is clear that angular distributions for atomic adsorbates are very sensitive to the surface structure so it is not unreasonable to anticipate similar effects for the Ni/CO system. Extensive calculations using the molecular dynamics procedure⁽⁵⁾ have been completed for the atop and twofold bridge bonding configurations but statistical considerations have restricted the analysis to only the Ni atoms. As shown in Figure 6 when the CO is in the A-top geometry, the calculated Ni distributions peak along azimuthal directions which are similar to the clean surface. For the twofold bridge case, however, the CO overlayer tends to randomly scatter the ejecting Ni atoms producing a much different pattern.⁽¹¹⁾ The predictions for the atop bonding geometry, when corrected for the presence of the image force, are in quite good agreement with experiment, and are consistent with the wide range of other experimental data available for the system.

Adsorption of CO on Ni{7 9 11}. Since the azimuthal angle distributions are sensitive to subtle differences between surface structures, it is of interest to examine the role of larger surface irregularities such as surface steps on the measured quantities. For example, suppose the orientation of the primary ion beam in the SIMS experiment is fixed at different azimuthal angles with respect to the step edge. If the ejection process is structure-sensitive, then changes in yield and cluster formation probabilities should be observed as the ion bombards "up" or

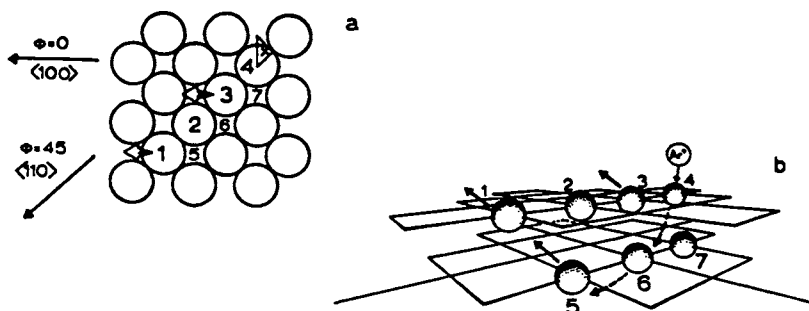


Figure 5. Mechanism of formation of the Ni_2 dimer which preferentially ejects in the $\langle 100 \rangle$ directions contributing the majority of intensity to the peak in the angular distribution. (a) $\text{Ni}(001)$ showing the surface arrangements of atoms. The numbers are labels while the X denotes the Ar^+ ion impact point for the mechanism shown in Figure 8b. Atoms 1 and 3 eject as indicated by the arrows forming a dimer, which is preferentially moving in a $\langle 100 \rangle$ direction. (b) Three-dimensional representation of a Ni_2 dimer formation process. The thin grid lines are drawn between the nearest-neighbor Ni atoms in a given layer. For graphical clarity, only the atoms directly involved in the mechanism are shown. Reproduced with permission from Ref. 6. Copyright 1980, American Physical Institute.

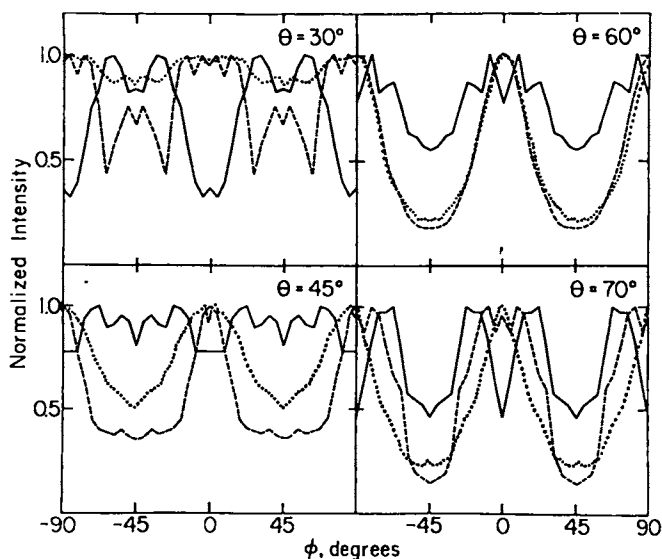


Figure 6. Predicted Azimuthal dependence of the Ni^+ ion yield for $\text{Ni}(001)c(2 \times 2)\text{-CO}$ for CO adsorbed in atop (---) and twofold sites (—). Only those particles with kinetic energies of 3 ± 3 eV were counted. Experimental points (••••). Reproduced with permission from Ref. 11. Copyright 1984, Springer-Verlag.

"down" the steps. In addition, the desorption of chemisorbed molecules should be influenced by their proximity to the step edge.

Carbon monoxide chemisorption on Ni(7 9 11) represents an interesting case with which to check these concepts since comparable studies have been performed on Ni(001) and Ni(111) and since a number of other experimental methods have been applied to this system. Electron energy loss spectroscopic (EELS) studies performed at 150 K suggest that the initial adsorption occurs in threefold and twofold bridge sites along the step edge. Beyond this point, the CO molecules begin to occupy terrace sites.⁽¹²⁾ Thus, the low temperature adsorption of CO on Ni(7 9 11) presents a realm of interesting structural phases which should be sensitive to the azimuthal angle of incidence of the primary ion beam.

The experimental results for the NiCO⁺ ion yield as a function of angle is illustrated for this system in Figure 7 and the angles are defined in Figure 8. Note that the cluster ion yields are higher at $\phi = 180^\circ$ than at $\phi = 0^\circ$, with the most significant variations occurring at intermediate angles. At 0.2 L exposure, the NiCO⁺ ion signal shows a broad peak which appears at $\phi = 115^\circ$. This peak shifts slightly to 105° and sharpens somewhat at an exposure of 0.4 L. By 0.6 L exposure the peak has become very intense and is only 10° wide, centered at $\phi = 100^\circ$. As the CO coverage increases this peak becomes very broad. At the saturation exposure of 2.8 L the NiCO⁺ ion intensity displays a broad maximum between $\phi = 40^\circ$ and $\phi = 160^\circ$. An exposure of 0.6 L corresponds almost exactly to the exposure at which the EELS results indicate that all the CO molecules were bound to adsorption sites near the step edge and that all the edge sites were occupied.⁽¹⁰⁾ Apparently, the specific bonding site of the CO next to the step edge is responsible for the sharp peak in the NiCO⁺ ion signal at $\phi = 110^\circ$. At saturation, the peak loses this definition completely, presumably since the CO molecules occupy several sites. At CO exposures performed at room temperature the azimuthal plots do not exhibit such sharp features, as illustrated in Figure 7. Calculations performed for the twofold bridge step-edge adsorption geometry corresponding to the 0.6 L exposure point successfully reproduce the sharp feature at $\phi = 120^\circ$, although it has not yet been possible to identify the specific collision mechanisms that cause it to occur.⁽¹³⁾

Angle-Resolved SIMS Studies of Organic Monolayers. We have seen how the angular distributions reflect the bonding geometry of adsorbates through analysis of the azimuthal anisotropies and by varying the angle of incidence of the primary ion. The next possibility is to see if there are channeling mechanisms which act perpendicularly to the surface and which manifest themselves in the polar angle distributions. The model systems which illustrate this effect are benzene and pyridine adsorbed on Ag(111) at 153 K. These model systems are of interest for a number of reasons. (i) The molecules are similar in size and shape and should behave in a closely related fashion under the influence of ion bombardment. (ii) Classical dynamics calculations have been performed on these molecules adsorbed on

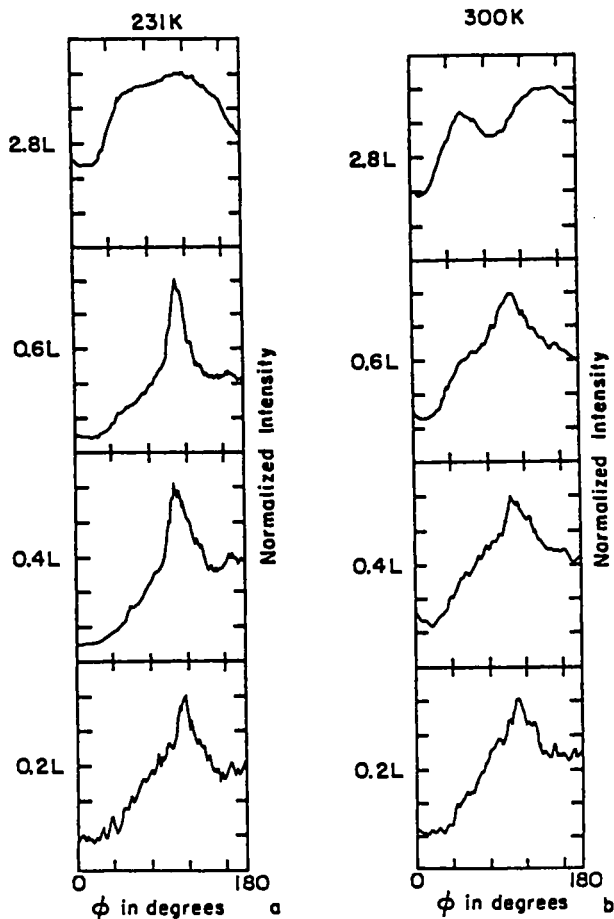


Figure 7. Normalized NiCO^+ intensity versus azimuthal angle ϕ as a function of CO exposure. Reproduced with permission from Ref. 13. Copyright 1984, American Institute of Physics.

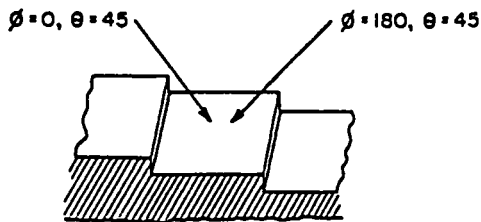


Figure 8. Definition of the polar (θ) and azimuthal (ϕ) angles of incidence of the primary ion beam relative to the $\text{Ni}\{7\ 9\ 11\}$ surface. Reproduced with permission from Ref. 13. Copyright 1984, American Institute of Physics.

Ni(001) where dramatic differences in the molecule yield are predicted to occur with molecular orientation.(14) (iii) Electron energy loss spectroscopy indicates that pyridine on Ag(111) initially adsorbs in π -bonded configuration but undergoes a compressional phase transition to a σ -bonded configuration as the coverage is increased.(15) Benzene, on the other hand, is believed to remain in the π -bonded configuration at all coverages.(16) A more detailed discussion of these effects is presented in reference 1.

Angular Distributions of Neutral Atoms Desorbed From Single Crystal

Most experimental studies aimed toward determining the angular distributions of secondary particles have focussed on the measurement of the secondary ions. The reason for this emphasis is that there have been no techniques available for detecting the neutral species with monolayer sensitivity. It would be extremely valuable to be able to perform these experiments to be able to obtain data that was directly comparable to the classical dynamics calculations and to get some insight into how the secondary ion fraction is affected by the take-off angle.

In this section, we describe a new apparatus and some preliminary results, aimed at providing detailed trajectory information on the ejected neutrals. It is based on a time-of-flight measurement for the neutral energies, multiphoton resonance ionization (MPRI) for the particle selectivity,(17) and two-dimensional position sensitive detection for the angular information. The detector is operated in an ultra-high vacuum environment, on well-characterized surfaces, and with low primary ion dosages onto the sample. A schematic representation of the experiment is illustrated in Figure 9. The desorption is initiated by a 0.2 μ s, 5 KeV Ar⁺ ion pulse incident on the sample at 45° focussed to 0.2 cm², and ionization is accomplished by absorption of photons from a 5 ns laser pulse obtained from the output of a Nd:YAG pumped dye laser. Under the present operating conditions we can detect neutrals whose kinetic energies vary from 0.2-50 eV into a total enclosed angle of over 100°. A complete analysis may be performed using a total dose of less than 10¹² incident Ar⁺ ions/cm². A detailed description of the apparatus will be given elsewhere.(18)

Using this detector, we have initiated a series of experiments aimed at determining the energy and angular distributions of Rh atoms ejected from clean and adsorbate covered polycrystalline and single crystal surfaces. Rhodium atoms may be efficiently and selectively ionized using 312.4 nm laser light, obtained by frequency doubling the output of the dye laser. From the polycrystalline material, we find the velocity distribution of Rh atoms follows closely the form predicted by Thompson(19) with a peak intensity occurring at ~5 eV and a high energy tail decreasing in intensity as E⁻². Polar angle distributions exhibit nearly a cos² shape. From a Rh{001} crystal, the velocity distribution generally peaks at a higher value than that found from the polycrystalline surface, and depends strongly on the value of the polar collection angle. For

example, the energy of the emitted atoms tend to be distributed about higher kinetic energies when the polar angle is chosen to coincide with a peak in the atom intensities, a result in qualitative agreement with classical dynamics calculations.

In addition to energy distribution measurements into a given angle, we are able to extract angular distribution measurements of particles with a given energy. Polar distribution measurements at a given azimuth from Rh(001) show three peaks of preferred ejection angles. The position of these peaks are predicted well by the classical dynamics calculations as shown in Figure 10. Of particular interest is the peak observed normal to the surface. This normal ejection peak is more prominent at 30 eV than at 10 eV which corresponds to an energy distribution with a larger high-energy tail. Variations in the relative intensity of this center peak relative to the side peaks are observed when an adsorbate such as sulfur is placed on the crystal surface. A preliminary example of this effect is shown in Figure 11. It is hoped that these variations, when coupled to computer simulations of the ion impact event, will lead to a new approach for characterizing such adsorbates.

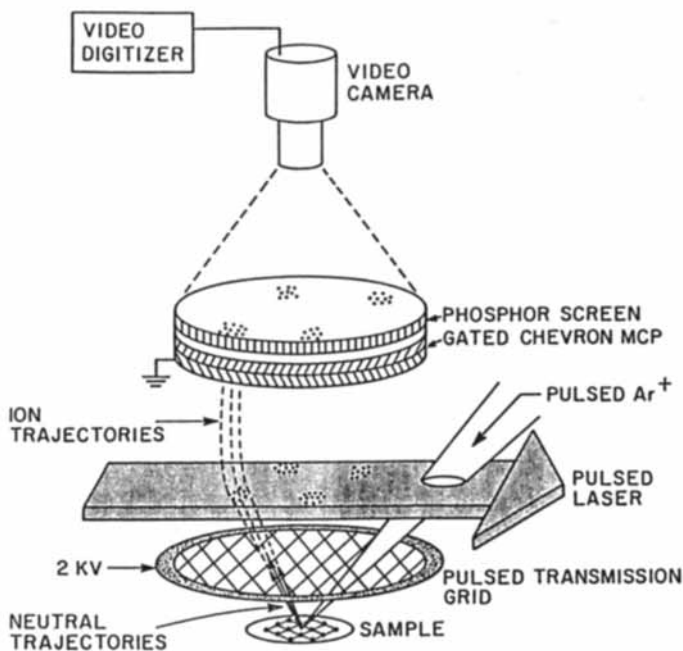


Figure 9. Detector for performing energy and angle-resolved measurement of neutrals desorbed from surfaces.

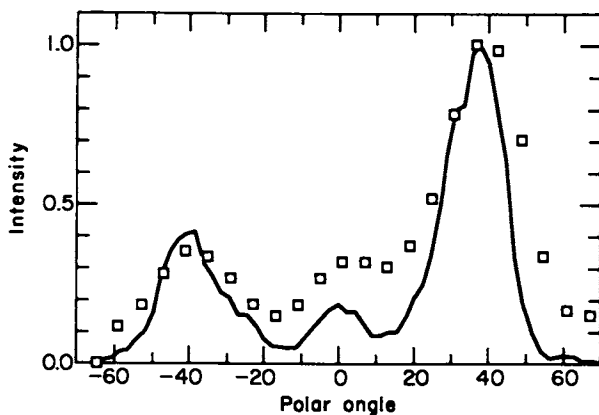


Figure 10. Measured angular distributions from clean Rh(001). Rh atoms with kinetic energies between 2 and 34 eV are collected. The points represent experimental data while the line represents calculated results. The crystal is aligned along $\phi = 0^\circ$.

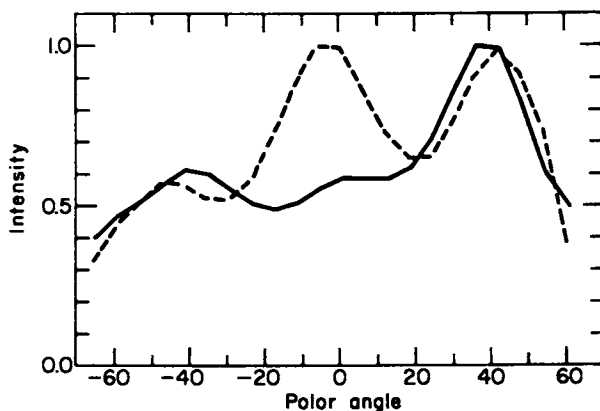


Figure 11. Measured angular distributions for clean Rh(001) (—) and Rh(001) covered with approximately 10% of a monolayer of sulfur (---). Rh between 2 and 8 eV are collected. Surface cleanliness as coverages were estimated using Auger spectroscopy.

Conclusions

It is hoped that the experimental examples discussed in this paper, together with the numerous comparisons to classical dynamics calculations, yield convincing evidence that the ion bombardment phenomenon is becoming well-understood. Of particular interest is the fact that the trajectories of the secondary ions appear to follow reasonably closely those of the calculated neutrals. In addition, angle and energy-resolved measurements may provide a new approach for elucidation of the structure of single crystal surfaces.

Acknowledgments

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Secondary Ion Mass Spectrometer Design Considerations for Organic and Inorganic Analysis

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This paper describes, in detail, the various instrument design aspects which must be considered when building a secondary ion mass spectrometer for organic and inorganic analyses. The nature of the information desired from these two kinds of analysis is very different, so it is not surprising that the secondary ion mass spectrometers specifically designed for organic and inorganic analyses are also quite different. Major component areas such as primary ion beam, secondary ion optics, mass spectrometer, detection and vacuum systems are discussed.

The technique of secondary ion mass spectrometry (SIMS) is one of extremely large scope. By using energetic particle bombardment of a surface and detecting with a mass spectrometer the charged particles which are emitted, one can

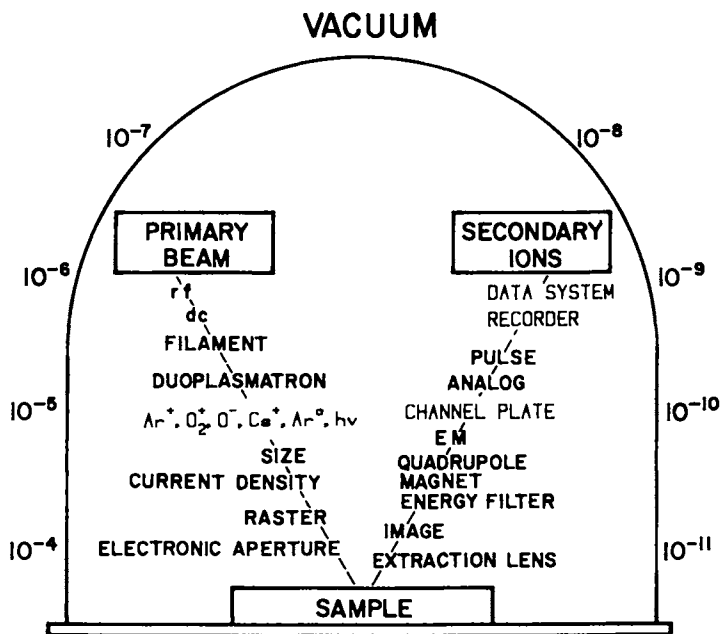
- (1) detect elements or molecules;
- (2) detect ions ranging in mass from 1 to >5000 Daltons
- (3) detect concentrations of constituents ranging from 100% to a part-per-billion
- (4) generate the detected signal from the first monolayer of the sample surface or sputter to depths greater than 10 μm below the original surface

Not surprisingly, however, all of these capabilities are generally not achieved within a single SIMS instrument. It is necessary to examine critically the requirements at hand and choose those design features which lead to an instrument best suited to the defined need.

The features from which one has to choose in building a SIMS instrument are as numerous and varied as the problems which the technique can address. Shown conceptually in Figure 1 are the various choices for primary bombarding beam formation and emitted particle detection, all encompassed within a vacuum system.

The ion source can be of a number of different types capable of making ions of a large variety of atoms. One may also bombard the surface with a beam of energetic neutral atoms or a photon beam

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Aldehyde/Ketone Derivatization

Figure 1. Schematic representation of a secondary ion mass spectrometer.

generated by a laser. The beam size and current density are important, and depending on the application, one may wish to raster the primary beam and use electronic signal gating techniques to spatially select the area from which to accept the signal. The sample may be a bulk solid, thin film, monolayer, or a liquid.

The system for mass analysis and detection of the emitted ions also involves many choices of components. In order to transfer ions most efficiently from the sample to the mass spectrometer, one may choose to use an ion extraction lens. Depending on requirements, this lens may or may not be of the image-forming immersion type. Most instruments will require some kind of energy filter to select the kinetic energy of the ions entering the mass spectrometer. The mass spectrometer itself may be a quadrupole, magnetic sector, or time-of-flight instrument with either a conventional electron multiplier or channel plate detector. The detector system can be operated in either the analog mode or the pulse counting mode with data handling ranging in complexity from a strip chart recorder to a computer data acquisition system.

Of course, everything except the electronics and data system associated with the SIMS experiment must be in a vacuum system, with the experimental results desired dictating the degree of vacuum required. This can range from ultra-high vacuum to pressures achievable with a simple diffusion pump.

System Requirements for Inorganic and Organic SIMS

When designing a SIMS instrument to give the best possible results for a given type of analysis one must know which components are necessary for the desired performance, and indeed, what kind of performance is required. Table I lists the three basic areas of SIMS analysis to be discussed here. Under each type of analysis are listed the most appropriate components and design features.

Inorganic SIMS--Depth Profiling

Inorganic secondary ion mass spectrometry deals with the analysis of the elemental composition of a sample. Due to the fact that the sample must be sputtered away to generate a SIMS signal, the instantaneous sample surface from which the secondary ions are emitted continuously recedes into the bulk. If ions of interest are monitored as a function of analysis time, depth profiles of those elements in the solid are obtained. This is the analysis method most often used in inorganic SIMS. The requirements of this method of analysis dictate the design of the inorganic SIMS instrument. The quality of the primary ion beam of a depth profiling inorganic SIMS instrument is very important. It must be of high current density. In order to reduce crater edge effects, (1) the beam must be rastered 5 to 10 beam diameters on a side to produce a flat-bottomed crater from the center of which the data are taken. Ions generated from the sloping crater wall are rejected by an electronic aperture (2) or by the ion optics of the secondary ion extraction lens (discussed later). In addition, it is important that no energetic neutrals be allowed to hit the sample because they will create ions from the sloping crater walls (3,4) and these

Table I. Instrumental Requirements for Inorganic and Organic SIMS

	Inorganic SIMS Depth Profile	Organic SIMS SOLID Surface	Organic SIMS LIQUID Surface
PRIMARY BEAM	>High Current Density >10 - 100um Diameter >Rastered >No Neutrals >Mass Analyzed	>Low Current Density >100um Diameter >Rastered >No Neutrals	>High Current Density >100um Diameter >Non-Rastered >Ions or Neutrals
SECONDARY ION OPTICS	>Immersion Lens >Electrostatic Analyzer	>Immersion Lens >Electrostatic Analyzer >Dynamic Emittance Matching	>Immersion Lens >Electrostatic Analyzer
MASS SPECTROMETER	>Large Quad or Sector >High Abundance Sensitivity >Mass Range 1 - 240 >High Mass Resolution	>High Mass Quad or Sector >Mass Range 10 - 1000 >Low Mass Resolution	>High Mass Quad or Sector >C.I.D. >Mass Range 60 - 5000 >High Mass Resolution
DETECTION SYSTEM	>Pulse Counting >Data System	>Pulse Counting >Chart Recorder	>Analog >Data System
VACUUM	>UHV	>UHV	>HV
OPERATIONAL MODE	>Scanning >Selected Ion Monitoring	>Scanning	>Scanning

ions will not be rejected by electronic gating. Mass analysis of the primary beam is generally desirable to insure that no impurities are present in the beam. Such species will become implanted into the sample and preclude their analysis at low concentrations in a sample (2).

Once secondary ions are generated from the analysis area of interest, it is essential to transmit them from the sample surface to the entrance slit or aperture of the mass spectrometer. This is most often done with an immersion lens, so named because the sample is "immersed" in the electric field of the lens (2,5). An electrostatic analyzer (ESA) is also needed to select an energy bandpass of secondary ions for the mass spectrometer. This is needed in inorganic SIMS because atomic ions emitted from the surface have an energy spread of several tens of electron volts. In addition, an ESA serves to block the line-of-sight from the sample surface to the mass spectrometer making it impossible for backscattered primary ions and emitted photons to generate a background signal in the electron multiplier ion detector.

The mass spectrometer used in inorganic SIMS can either be a magnetic sector instrument or a quadrupole instrument. It need only have a mass range of 1 to 240 in order to measure all atomic ions in the periodic table. This small mass range is beneficial because it allows one to use a quadrupole rod structure with large diameter rods thus increasing ion transmission. Alternatively, with a sector-type instrument one can use a high accelerating potential which also improves ion transmission. For many materials problems it is also desirable to have a mass spectrometer capable of high mass resolving power for separation of closely spaced peaks in the mass spectrum which occur at the approximately same nominal mass (6).

The detector system used in most inorganic SIMS instruments consists of a discrete dynode electron multiplier feeding ultrasensitive, high speed pulse counting electronics. A charge sensitive amplifier capable of detecting 10^4 - 10^5 electrons at 100 MHz (7) should be used along with an electron multiplier capable of delivering count rates >10 Mc/s with no gain degradation and with low background (<0.1 c/sec). The 6-7 order-of-magnitude range in signal intensity observed in inorganic SIMS requires such elaborate ion detection schemes. One must also consider the vacuum required in the sample chamber during analysis.

Ultra-high vacuum is desirable in the vicinity of the sample in order to keep the sample "clean" during analysis. Molecules from the residual gas strike the sample at a rate equivalent to one monolayer/sec at 10^{-6} torr. Elements striking the sample from the residual gas such as H, C, O and N are analyzed as though they were originally present in the sample thus yielding an anomalously high concentration for these species.

Organic SIMS - Solid Surfaces

Organic SIMS, as the name implies, deals with the sputtering and ionization of organic molecules from surfaces. The ability to detect sputtered ions of organic molecules was first reported by Benninghoven (8) who studied the emission of intact amino acid ions

from a solid surface. An instrument suited for such analyses evolves quite naturally from an inorganic SIMS instrument. As Table I shows, many of the design requirements are the same yet there are several important differences which make this type of machine very special.

Of primary importance when sputtering organic molecules is that those molecules have many interatomic bonds which can be broken easily by the impact of the primary bombarding particle. In order to prevent the sputtering of severely damaged molecular fragment ions of little analytical significance, it is necessary to limit the experiment such that ions are emitted only from regions of the sample which have not been damaged by previous primary particle bombardment. Practically speaking, this generally means that a complete spectrum must be taken before 10% of the uppermost monolayer of sample has suffered radiation damage. Otherwise, the probability of ion emission from a previously damaged region will be appreciable (9). One can understand readily that this type of analysis is extremely sample limited (10% of one monolayer). In order to obtain the largest signal possible, or to obtain a useable signal for as long a time as possible, one must design an instrument which sputters and extracts ions from as large an area of the sample as possible. It is this requirement that sets this kind of SIMS instrument apart from all others.

For optimum performance, an instrument designed to detect organic ions from solid surfaces should use a primary ion beam of low current density and relatively small size. The beam should not contain any energetic neutral particles, and it should be rastered. The reasons behind these requirements are intimately related to the need for large-area secondary ion generation and extraction and will be covered in the discussion. For analysis of nonconducting surfaces, a beam of energetic neutral atoms may have to be employed to reduce sample charging. But due to the extremely low fluences used in organic surface layer analysis, ion beams will usually not result in severe sample charging.

The secondary ion optics required for large-area ion extraction are very specialized and will also be covered in the discussion. They involve an immersion lens and dynamic matching of the ion emission point with the entrance aperture/slit of the mass spectrometer. Again, an ESA is needed, more however, to filter out high-energy neutral particles and photons than to energy-filter the secondary ions because organic molecular ions are emitted with a characteristically low spread of kinetic energies (9).

The mass spectrometer used in organic SIMS of solid surfaces may be a quadrupole, magnetic sector, or time-of-flight type, but should preferably have a mass range to approximately 1000 D. Low mass resolving power is used because the signal levels are generally too low for use with high mass resolving power spectrometers which have lower ion transmission factors.

Like their inorganic counterparts, solid-surface organic SIMS instruments use single-ion detection schemes except that the high count rate requirements are not so severe. There is, however, the possibility of using a magnetic sector spectrometer with Mattauch-Hertzog geometry and photoplate or microchannel plate detection. This is advantageous because all masses are collected simultaneously, thus making maximum use of the secondary ions generated.

The vacuum requirements for this type of SIMS instrument are extremely stringent because the uppermost monolayer of the sample must not become contaminated by the residual gas in the instrument, otherwise the spectrum observed will bear little resemblance to the actual sample surface.

Organic SIMS - Liquid Surfaces

Several years ago, a novel sample preparation technique was developed (10) for sputtering intact organic molecules from surfaces. The key feature of the technique is the use of a viscous, non-volatile liquid surface from which to sputter and generate organic secondary ions.

The actual momentum transfer process involved in sputtering (11) is the same for liquids and solids due to short time duration (picoseconds) of a collision cascade during which the atoms of a liquid are essentially motionless (9). However, during the time between successive impacts of primary particles on a given 100\AA^2 area on the sample surface (approximate area damaged by primary particle impact), the molecules of a liquid can move considerable distances. Typical molecular velocities are 30 m/sec. (9) This means that as fast as the uppermost surface monolayer is damaged by primary particle bombardment, it is mixed into the liquid bulk by diffusion and replaced by new, undamaged material. This liquid-phase mixing allows large fluxes of primary bombarding particles to be used while still maintaining an undamaged surface monolayer from which to emit secondary ions. The large bombarding flux will, in turn, produce a large flux of secondary ions, large enough to be used by a more conventional organic mass spectrometer.

As just mentioned, a liquid surface organic SIMS instrument should use a high flux primary bombarding beam. It may be an ion beam or a beam of energetic neutral atoms. In either case, it should have a small diameter for reasons which will be made clear in the discussion. Care must be taken, however, to keep the current density of the bombarding beam within reasonable limits (several mA/cm^2) in order to keep within this damage/mixing regime. Ion sources of exceeding high brightness, such as field emission guns, can produce ion beams capable of being focussed to current densities approaching $1\text{ A}/\text{cm}^2$. Under these conditions, the time between successive primary ion impacts within the 100\AA^2 area of damage would be so short that the mixing of the damage into the bulk could not occur from one primary ion impact to the next.

The secondary ion extraction optics should include an immersion lens above the sample surface to maximize secondary ion transmission from the sample surface to the mass spectrometer. An electrostatic analyzer should again be used to filter out high-energy neutral particles and photons from the secondary ion beam. Energy analysis of the secondary ions is generally not necessary, but can be used to vary the amount of fragmentation observed in the mass spectrum (9).

The rest of the mass spectrometer can be a conventional organic instrument. High mass quadrupole mass filters or magnetic sector instruments may be used. A mass range to 5000 D is advis-

able to make use of the measurable ion currents of very large molecular ions of biomedical importance which can be generated using the liquid-matrix techniques. One may also employ high mass resolution and collision induced-dissociation techniques due to the large secondary ion currents available. Ion detection may be in the analog mode, and most importantly, conventional mass spectrometry data acquisition systems may be used because of the large ion currents available. Vacuum requirements are not stringent because the pressure and residual gas composition are dictated by the organic liquid being used for the sample matrix.

Discussion

In the previous section, we discussed the general design objectives of SIMS instruments used for three specific types of analyses: 1) elemental depth profiling analyses; 2) organic analyses of solid surfaces; and 3) organic analyses of liquid surfaces. Again, these design features are shown in Table I. If, however, one examines Table I more closely, and with a horizontal emphasis instead of the previous vertical emphasis, one can see that several design features are desirable in all SIMS instruments. Under the **Primary Beam** category, one sees that all three types of SIMS instruments should use small diameter bombarding beams. Under **Secondary Ion Optics**, one will notice that the use of an immersion lens for secondary ion extraction is always desirable, as is an electrostatic energy analyzer. These two critical categories will be discussed in this section, but they will be discussed in reverse order, starting with Secondary Ion Optics, for reasons which will become apparent.

Secondary Ion Optics

Strictly speaking, the term "secondary ion optics" refers to all those ion-optical components which transmit secondary ions from the sample surface to the detector. For the sake of this discussion we will limit the scope of the term to those secondary ion-optical components between the sample surface and the mass spectrometer. With this restriction, we see that the purpose of the secondary ion optics is to extract the ions efficiently from the sample surface and present them to the entrance of the mass spectrometer in a satisfactory manner. Recognition of three important facts are necessary for such ion optics design:

- 1) Secondary ions are emitted from the sample surface with a cosine distribution centered about the sample surface normal as shown in Figure 2.
- 2) The geometrical and/or electrical entrance apertures of mass spectrometers are very small.
- 3) The Liouville Theorem states that one can extract and transmit ions emitted from a large area on the sample surface with a narrow angle of divergence, or one can extract and transmit ions emitted from the surface with a large angle of divergence, but only from a small area on the sample surface. But one cannot simultaneously extract ions with large angular divergence from a large area.

The consequences of these boundary conditions strictly limit the secondary ion transmission efficiency of the instrument and thus, ultimately, the sensitivity of the analysis.

In order to obtain high sensitivity the secondary ion optics must be capable of transmitting to the mass spectrometer those ions which are emitted at large angles with respect to the surface normal. This is best accomplished with an immersion lens(12) placed close to the sample surface as shown in Figure 3. The lens should form a real image of the sample surface in an image plane which then must be "transferred" to the entrance of the mass spectrometer with transfer optics. The net result is that a large fraction of the ions emitted from a point on the sample will be imaged onto the entrance aperture of the mass spectrometer resulting in high transmission efficiency and sensitivity.

At this point, it is appropriate to consider the size of the entrance aperture of the mass spectrometer. Double-focusing magnetic sector instruments have entrance slits only micrometers wide. Clearly, if a real ion-image of the emitting surface is illuminating this aperture, only those ions originating from a very small area of that emitting surface will be passed into the mass spectrometer. Thus, it is inadvisable to design a liquid surface organic SIMS instrument which uses a large diameter (millimeters) bombarding beam because only those ions emitted from a 10-100 micrometer diameter area of the sample surface will be passed into the mass spectrometer. Any primary beam falling outside this area will only contribute to radiation damage of the sample and not to the analytical signal. Therefore, small diameter, focusable ion beams are recommended for this application for most efficient sample utilization.

One might think that quadrupole mass spectrometers would be less susceptible to this limitation because of their much larger entrance apertures. Unfortunately, this is only marginally true, and only for ions of low mass. This is because the electrical entrance aperture of the quadrupole is usually considerably smaller than the physical entrance aperture. By "electrical entrance aperture" we mean that area of the physical entrance aperture through which ions must travel if they are to be transmitted through the quadrupole rod structure. The radius of this aperture, r_q , is small and mass-dependent as seen by the following equation

$$r_q = 2/3 r_o (\Delta M/M)^{1/2} \quad (1)$$

where r_o is the radius of the largest circle that can be inscribed within the four quadrupole rods, and $\Delta M/M$ is the mass resolution of the spectrometer(13).

Consider a quadrupole mass spectrometer with 6mm diameter rods operating at a mass resolving power of 600 (which is needed for high mass organic liquid surface SIMS). The radius of the electrical entrance aperture is only 0.07mm (0.003"). This also makes a very small target for the secondary ion optics to "hit" with the ions being emitted from the sample. The optics can function much more efficiently in transmitting ions from the sample surface into the mass spectrometer if the secondary ions are being

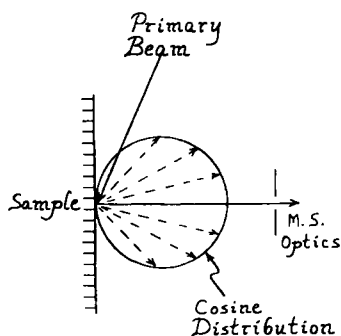


Figure 2. Cosine distributions of sputtered particles. The length of the arrow is proportional to the probability of ion emission in that direction.

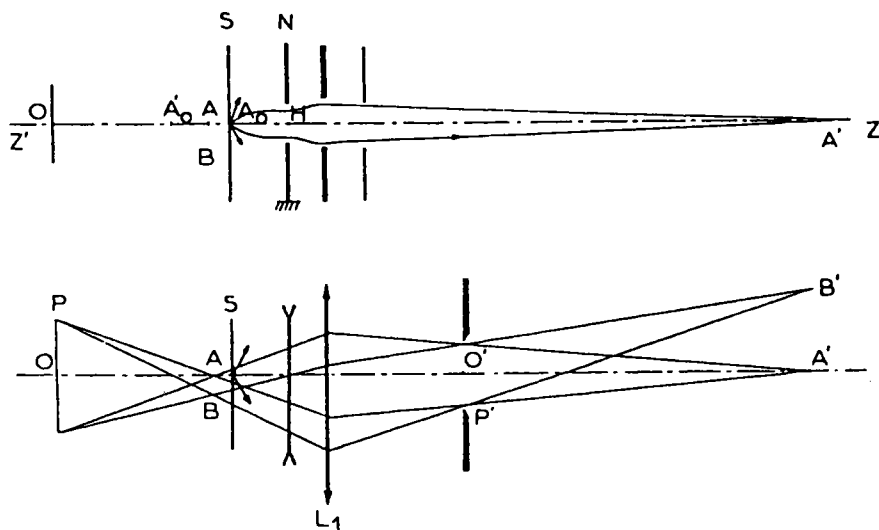


Figure 3. Immersion lens a uniform field E_0 is set up between the target S and an electrode N (at ground potential). S and N are parallel. The ions emitted at point A_0 of the flat surface of object S are accelerated by this uniform field. The ions escape from the accelerating field through a round hole (T) in N. The optical axis of the system of collection is the axis ($z'z$) of the hole, which lies perpendicular to the surface of the target. The hole T acts as a diverging lens. A unipotential lens L_1 , with a $z'z$ axis projects the virtual image A of the surface in a real image A' . At the same time, this lens produces a real image of the crossover over which a "contrast" diaphragm can be placed. The diameter of the diaphragm limits a diameter on the initial virtual pupil and therefore the sample area from which ions are accepted. Reproduced with permission from Ref. 5 copyright 1980, Academic Press.

emitted from a small spot on the sample surface (because of the Liouville theorem). Therefore, small (50–150 μm) diameter primary ion beams should always be used for sputtering.

But what about extracting organic secondary ions emitted from a solid surface where one desires to sputter the surface over a large area so that no one spot accumulates a high amount of radiation damage? The Liouville theorem specifically states that one cannot extract a large number of secondary ions (those ions with a large angle of divergence) from such a large area as would be required for a highly sensitive analysis. The solution to this problem of efficient ion extraction from large areas is called "dynamic emittance matching". As first described by Liebl (14), the technique provides a clever ion-optical path around the restrictions of the Liouville theorem.

Optimum transmission of secondary ions is achieved when the acceptance of the mass spectrometer is matched with the secondary ion beam. Figure 4a shows schematically the transfer of the secondary ion beam from the sample to the mass spectrometer entrance slit. If d_1 is the diameter of the area to be analyzed, the entrance slit (width s) has to accept the image $d_1 + \delta_1$ which is $d_2 + \sigma_2$. σ_1 is the virtual width of the sample point, given by $\delta_1 = V_1^2/E$ where V_1 is the initial kinetic energy and E is the field strength on the surface. This explains the desirability for high extraction fields at the sample surface). Using the Liouville theorem, we obtain

$$(d_1 + \delta_1) \alpha_1 = s \alpha_2 \quad (2)$$

This results in a certain beam divergence α_2 of which only the angle α_1 is accepted by the mass spectrometer. This is the case whether a large, stationary beam irradiates the entire width d_1 , or a fine beam probe is raster scanned over d_1 . This represents the state of the art for virtually all solid-surface organic SIMS instruments. However, if a fine scanned primary beam is used, the transmission can be improved considerably by using dynamic emittance matching shown in Figure 4b. In this scheme, the secondary ion beam transfer optics incorporates a deflector synchronized with the primary beam movement so that the movement of the virtual source spot δ_1 is cancelled. Instead of the previous equation, the following condition must now be met

$$d_1 \alpha_1 = s \alpha_2 \quad (3)$$

with the same slit width s and α_1 . The final beam divergence α_2 in this case is now smaller by a factor of $(d_1/\delta_1) + 1$ and accordingly, more of the secondary ions fall within the acceptance angle of the mass spectrometer.

Dynamic emittance matching has been applied with great success in the field of organic solid surface SIMS analysis by Campana and co-workers (15) and by Benninghoven and co-workers (16), but due to the sophistication required, this technique has not yet seen wide use in the field. Nevertheless, as analytical requirements call for higher sensitivity, especially for high mass ions, dynamic emittance matching will be required.

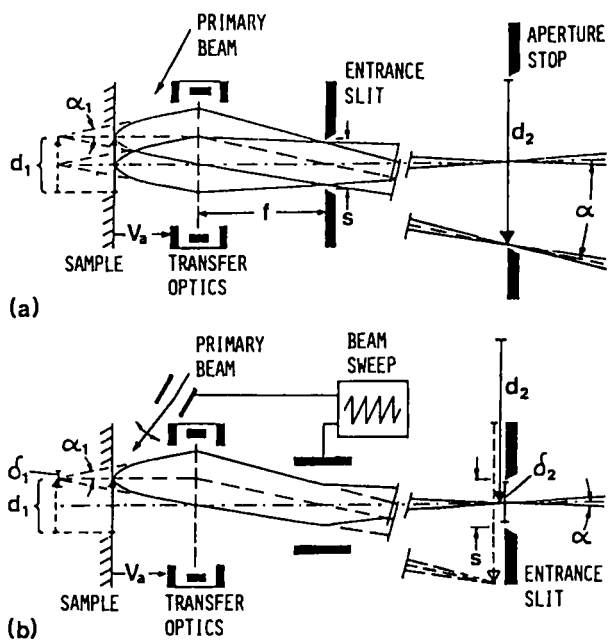


Figure 4. Secondary ion Transfer from sample to mass spectrometer.

- a) static beam transfer
- b) dynamic beam transfer (dynamic emittance matching)

Future Trends in SIMS Instrumentation

While secondary ion mass spectrometry has been practiced for over 30 years, the technique is far from "mature". In fact, in the organic SIMS field, the technique is still in its infancy. Most of the desirable instrumental features outlined in this paper for organic SIMS instruments have yet to be incorporated into present-day machines. Most instruments currently being used for organic SIMS were originally designed for quite different purposes and have capabilities for SIMS far below those which are potentially available if currently available ion-optical techniques are used. This is particularly true in the liquid-surface organic SIMS field. None of the instruments use finely focussed ion beams to sputter only that area on the sample surface which will produce ions that can be transmitted by the mass spectrometer. For reasons which are unclear, the makers of magnetic sector organic SIMS instruments promulgate the mystique that it is difficult to direct a focussed ion beam into the sample region due to the high electric fields present when, in fact, this has been done ever since the beginning of SIMS (17).

Secondary ion extraction optics are also far from optimized. No currently commercially available organic SIMS instruments utilize an immersion lens for ion extraction. There is no question that the instruments in current use, even though not optimally designed for this purpose, have provided a wealth of information for organic chemists and mass spectrometrists. But what instrumentation are we going to need to solve tomorrow's problems? An area that is becoming increasingly important is the molecular characterization of solid surfaces. At present, we have no analytical techniques to probe this type of sample other than organic SIMS. Elemental characterization of solid surfaces can be obtained using a variety of techniques (SIMS, Auger electron spectrometry, X-ray photoelectron spectrometry, etc.). But when it comes to answering the question, "What molecules are present on my sample surface?", we are in great need of more sophisticated SIMS instrumentation. Besides an instrument with the features described here (small ion beams used with dynamic emittance matching, high transmission extraction optics, etc.), there are several other instrumental approaches which could provide exciting possibilities for high sensitivity molecular surface mass spectrometry. Optimization of time-of-flight instrumentation has obvious advantages due to high ion transmission and detection of all transmitted species. This area will undoubtedly see a great increase in interest in the near future.

Another exciting possibility for high sensitivity molecular surface mass spectrometry is the use of laser-excited ion desorption in a pulsed ion cyclotron resonance experiment using Fourier transform techniques. In an ideal situation, this scheme could include all those attributes which are desirable for solid-surface molecular characterization:

- 1) surface sensitivity due to laser desorption
- 2) high "transmission" due to the high collection efficiency of the pulsed ICR cell approach
- 3) high mass resolution
- 4) high mass range

These areas should provide some exciting avenues to explore in the coming years for organic SIMS.

But what about inorganic SIMS? Here the field is indeed more mature with the advent of the ims-3f by CAMECA:Thomson-CSF in 1978 (5). But there are still a few interesting instrumental aspects to explore, one of which is the application of ultra-finely focussed ion beams (18).

In the last several years, researchers have developed the liquid-metal field-ionization source to a high level of performance and reliability. Developed mainly for direct-writing ion implantation and ion beam lithography, these sources have the potential of greatly enhancing the capabilities of inorganic depth-profiling SIMS instruments. Their high brightness makes it possible to form beams $<1000\text{\AA}$ in diameter with current densities of many A/cm^2 . Unfortunately, however, the beam species available are limited mainly to Ga⁺ and In⁺ from metals which have low melting points and low chemical reactivity. These species produce none of the yield-enhancing characteristics (19) needed for high sensitivity analyses and may even reduce the yield of positively charged ions. In addition, these ion sources, due to their exceedingly small beam size not withstanding their high current densities, are severely limited in the total ion current deliverable to the target. This means that in order to obtain high sensitivity with these small beams, only the highest transmission mass spectrometers should be used. This limitation essentially rules out all quadrupole type instruments due to their limited transmission of ions with a wide energy spread as is the case with atomic secondary ions.

The liquid metal ion source could help dramatically in the area of negative secondary ion mass spectrometry where bombarding with Cs⁺ ions has proven very beneficial (19). This is due to the large increase in negative ion emission from a cesiated, low work function surface. Unfortunately, the sources used to produce cesium ions are of the surface ionization type (20) which has a low brightness. If the liquid metal field emission ion source can be developed to operate reliably with liquid cesium, then small, high-current density ion beams could be formed. Currently, however, the reactive nature of the metal makes the liquid metal field emission cesium ion source more of a research project than a routine analytical technique.

Summary

It has been the purpose of this paper to provide an overview of the basic differences and similarities of the various types of instruments which detect ionized particles emitted from surfaces by energetic particle bombardment. Since the scope of secondary ion mass spectrometry is so broad, it is not surprising that no one instrument has been designed to perform optimally for all types of SIMS analyses. Design aspects of the primary beam, extraction optics, mass spectrometer, detection equipment and vacuum system must be considered to construct an instrument best suited for a particular purpose.

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Liquid Metal Ion Sources

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Use of liquid metal ion (LMI) sources to produce secondary ions in the dynamic SIMS mode has yielded ion abundances of sugars up to 50 times greater than those produced with neutral argon beams and in the static SIMS mode has generated useful molecular weight information from as little as 6×10^{-17} mole of crystal violet and 2×10^{-13} mole of leucine-enkephalin. LMI sources permit broad variation of the mass and molecular type of the bombarding particles, a potentially useful feature for studies of secondary ionization of organic molecules. Construction of LMI sources, attachment to existing mass spectrometers, and operation are relatively simple.

The liquid metal ion (LMI) source is an electrohydrodynamic field emitter. Experimentally, it is known that emission takes place from a cone of liquid metal (1) which is formed by application of a relatively high electric potential and maintained by the resulting high electric field (2,3). The ion source operates with a variety of metals. For any given metal both ions and charged microparticles are emitted. The ionic component is comprised of singly and multiply charged atomic and molecular ions; Table I lists some of the ion species produced by LMI sources. The relative abundances of these different ions as well as their individual energy distributions and angular divergences are strongly dependent on the total emission current (4-15). Although it has not been studied as thoroughly as the ionic part, the charged microparticle component apparently accounts for about two-thirds of the ejected material at emitter currents less than 100 μA (16), and both the size and size range of the charged microparticles have been shown to increase measurably with increasing emission current (17,18). At present there are many unknown aspects concerning the ionization and ejection processes occurring at the apex of the emission cone; hence, a theoretical model consistent with the LMI source's emission properties has not yet been formulated.

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Table I. Selection of Ions Produced by LMI Sources

Element / Z	Ion Species (m/z, most abundant isotope)	
	+2	+1
Al	13.5	27, 54, 81, 108, 135
Si	14	28, 56
Ni	29	58, 116
Ga	34.5	69, 138, 207, 276
Se		80
Ag		107
In	57.5	115, 230
Sn	60, 180, 300, 420	120, 240, 360, 480
	540	600, 720, 840
Cs		133
Au	98.5, 295.5	197, 394, 591
Pb	104, 312	208, 416, 624
Bi	104.5, 313.5, 522.5	209, 418, 627
U		238

A LMI emitter is virtually a point source; thus, its principal, distinguishing, optical characteristic is its very high brightness which can be shown for a typical emitter to be on the order of 10^6 A/cm²sr (19). Focused beams that deliver 20-120 pA into spots of about 100 nm diameter at a convergence half-angle of 1 mrad ($1-5 \times 10^5$ A/cm²sr) have been achieved recently in the development of LMI sources for ion microprobe analysis of solids (20,21). This brightness feature is important to several charged-particle-beam techniques in microfabrication, ion beam lithography, maskless ion implantation, ion microprobe analysis, and ion propulsion (2,3,22,23). Consequently, there is considerable scientific and engineering interest in LMI sources.

Recently, this investigator and his colleagues began using LMI sources to produce ions from liquid organic solutions (24-28). This application was motivated by the potential for exploiting the LMI source's rich selection of ions and microparticles to investigate secondary ionization processes, the possibility of improving sensitivity, and the more remote prospect of achieving localized, molecular analysis of biological tissues with a finely focused ion beam.

The construction and operation of LMI sources are briefly described in the first section of this paper. The potential use of LMI sources in fundamental investigations of secondary ion emission from liquid organic matrices is discussed in the following section. The few existing preliminary reports on LMI/SIMS combinations used or studied for analytical purposes are reviewed in the final section.

Fabrication and operation

The two common configurations for LMI emitters are the capillary (2) and the needle (3), Figure 1. As its name suggests the

former, Figure 1a, utilizes a narrow capillary. Molten metal is drawn through the capillary from a reservoir to the end where the cone of liquid metal is formed. Although they can have very long lifetimes, these emitters are difficult to make and, to the best of this writer's knowledge, have not yet been employed for SIMS of organic compounds.

A needle source consists of a hairpin filament ($\sim 180 \mu\text{m}$ diameter), usually of a refractory metal such as tungsten, with a short length of smaller diameter ($\sim 125 \mu\text{m}$) wire spot-welded to it, Figure 1b. The tip of the latter wire, the emitter, is electrochemically etched to a point with a radius of curvature at the apex of 2-5 μm ; the etching technique for tungsten has been described in detail by others (7,29). As quickly as possible after the assembly is thermally cleaned under vacuum ($\sim 10^{-4}$ Pa), the emitter is dipped into a molten pool of liquid metal and then withdrawn. If done correctly, the junction formed by the bend in the filament and the emitter wire will hold a small bead of metal, and the emitter will appear shiny from the thin film of metal on its surface.

Certain details are important to the successful wetting and operation of a LMI source. The emitter wire must be of an element or alloy which is wettable by the liquid metal to be used in the source. Thermodynamical concepts and data found in handbooks (30) or reference books (31,32) can be useful for selecting compatible emitter-metal/liquid-metal combinations. It is generally necessary to remove the emitter's metal oxide skin before it can be wetted; this is accomplished in the electrochemical and thermal cleaning steps. Wetting of the emitter's shank and sharpened tip is further facilitated by chemical etching to groove and roughen their surfaces (7,29). The metal in the wetting reservoir should be kept scrupulously free of dust, oil, or other dirt. Scum on the reservoir's surface will be transferred to the emitter during wetting, and the source will not operate correctly or at all. It is useful to provide the wetting chamber with a viewing port to observe the emission pattern of a freshly wetted emitter as a simple performance test before removing it from the vacuum.

A LMI emitter's smallness makes it possible to attach it to the ion source of almost any magnetic sector or quadrupole mass spectrometer. Ion sources which have already been designed for fast atom bombardment (FAB) or field desorption (FD) are ideally suited to modification for LMI/SIMS operation.

For most analytical applications the LMI source can be employed in a simple unfocused form. A diagram of an unfocused LMI source appended to the side of a magnetic sector instrument's ion source is shown in Figure 2. Figure 3 exhibits a photograph of an actual source of this same design. More sophisticated LMI sources, which can be focused (24,28,33) and/or pulsed (33), have been designed to investigate ionization mechanisms and test sensitivity limits.

LMI sources with needle emitters operate in essentially the same way as field ionization or field desorption sources. The filament is resistively heated to melt the metal film and/or promote its flow to the tip of the emitter. Typically, the emitter or anode is positively biased 3-5 kV with respect to its counter electrode, the cathode; the actual operating voltage is determined

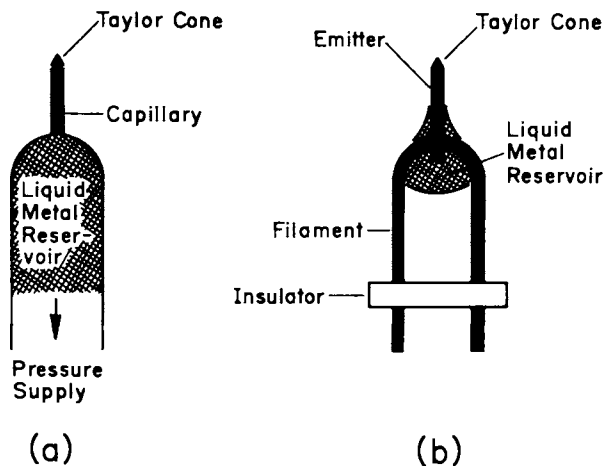


Figure 1. Liquid metal ion emitters: (a) capillary, (b) needle.

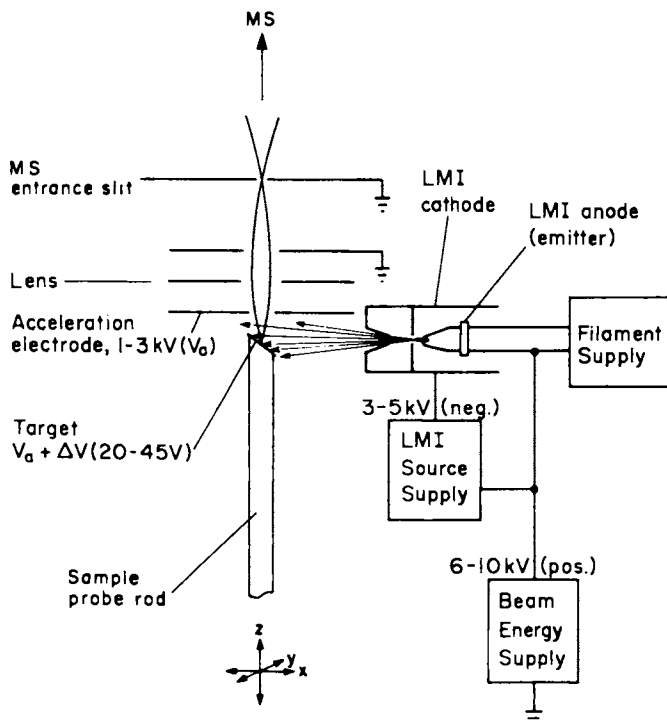


Figure 2. Schematic of a nonfocusing LMI source attached to the ion source of a single-focusing magnetic-sector mass spectrometer.

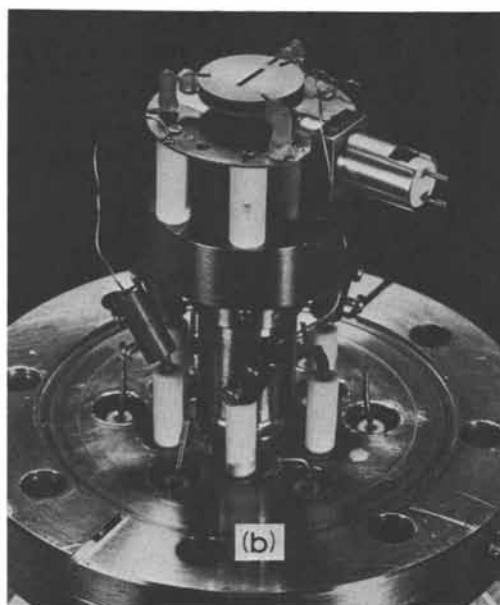
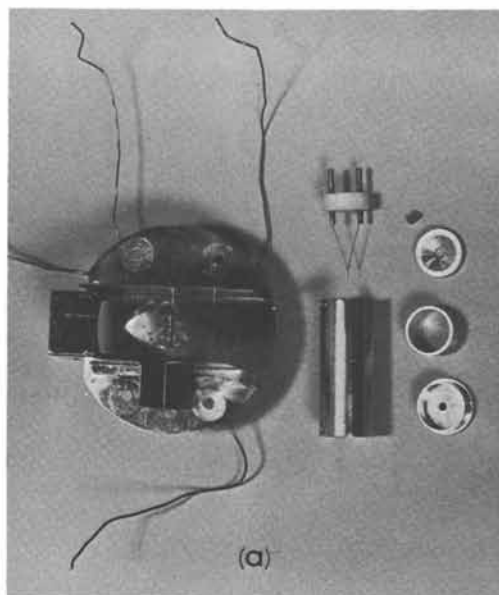


Figure 3. Photograph of a nonfocusing LMI source: (a) unassembled, (b) assembled and attached to the ion source of a single-focusing magnetic-sector mass spectrometer.

by the emission onset voltage, a quantity which is geometry dependent, and the desired emission current. The anode current is a convenient parameter for monitoring the source's emission. In an unfocused configuration the cathode can be maintained at the same potential as the acceleration electrode in the mass spectrometer ion source. This arrangement has the disadvantage, however, that the impact energy of the primary ions and the emission current are both determined by the LMI source's operating voltage. In order to separately control the primary beam current and energy, it is necessary to be able to vary the anode-cathode potential, i.e. the LMI source's operating voltage, independently of the emitter's potential. One method for accomplishing this is to float the power supply for the LMI source as illustrated schematically in Figure 2.

Investigation of secondary ionization processes

One of the most significant uses of LMI sources in connection with SIMS of organic compounds may be as probes in performing measurements of secondary particle yields. Such measurements are important for understanding the processes of secondary ion emission from solid and liquid organic samples. Total particle yields reflect directly the dynamical aspects of emission processes; variations in primary beam energy, incident flux density, and primary particle mass, for example, are all manifested in changes in total particle yields. The ratio of secondary ion yield to total particle yield and the ratio of secondary ion yields from two different species can be sensitive, quantitative monitors of the chemistry and kinetics, respectively, of ionization processes.

The particular advantage LMI sources offer to such experiments is a selection of prospective primary particles that spans a broad range of mass and molecular type. Some of the ions available from LMI sources are listed in Table I. Among the particles tabulated there are several groupings within which the effects of various particle types can be probed essentially independently of particle mass, e.g. $^{29}\text{Si}_2^+$ (58), $^{58}\text{Ni}^+$ (58), $^{116}\text{Sn}^{++}$ (58); $^{107}\text{Ag}^+$ (107), $^{27}\text{Al}_4^+$ (108); $^{27}\text{Al}_5^+$ (135), $^{69}\text{Ga}_2^+$ (138); $^{69}\text{Ga}_3^+$ (207), $^{209}\text{Bi}^+$ (209); $^{197}\text{Au}_3^{++}$ (295.5), $^{118}\text{Sn}_5^{++}$ (295); and $^{207}\text{Pb}_2^+$ (414), $^{118}\text{Sn}_7^+$ (413).

For example, experiments might be conducted with ions from one or more of these groups to distinguish between linear and nonlinear collision processes (34). This author and his co-workers recently described an apparatus that combines a LMI source and a Wien filter to produce a focused beam of particles which are selected by mass and type (28). When completed, this versatile probe will be used to investigate secondary emission from liquid organic matrices.

This same group of investigators has also been developing a combined gravimetric/scintillation counting technique for measuring total secondary particle yields from liquid organic solutions (28,35). Preliminary results, Figures 4 and 5, from measurements on glycerol solutions are surprising. The total particle yields from glycerol bombarded by 3-5 keV indium ions are in the range of 1000-4000, two to three orders of magnitude higher than those generally observed for metals in this energy range. The yields for moderately concentrated sugar solutions appear to be twice as large

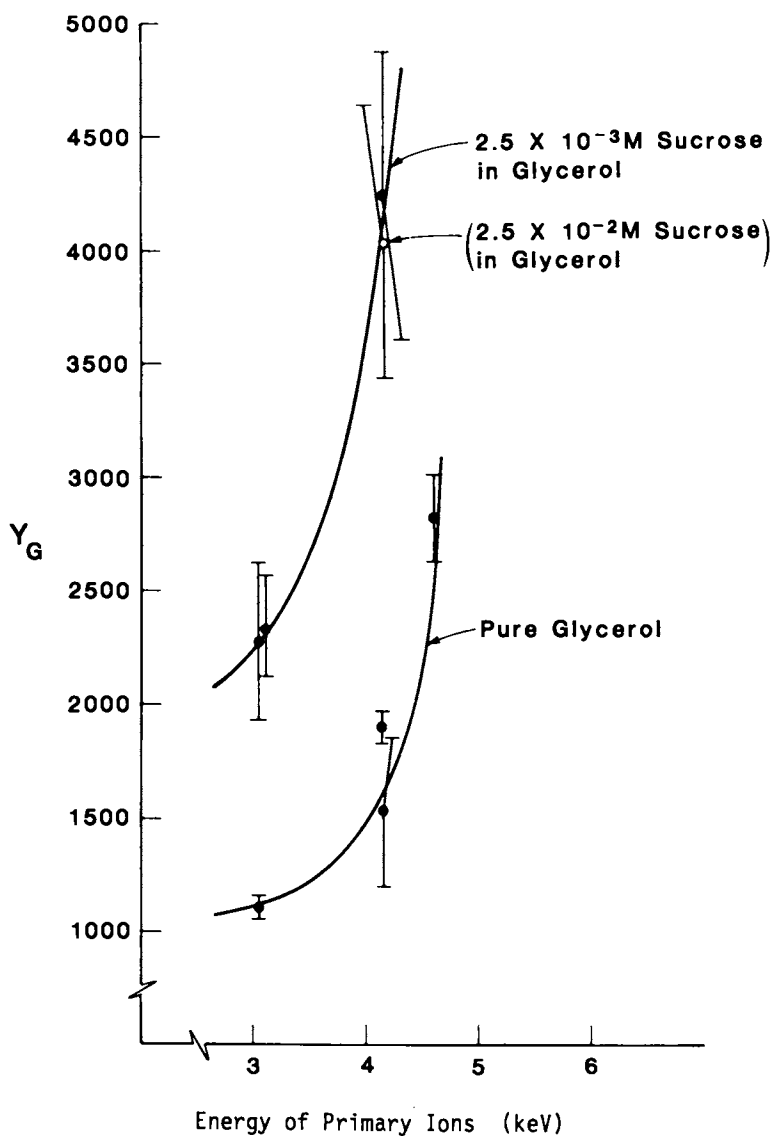


Figure 4. Total particle yields of glycerol versus primary ion energy: In-LMI source.

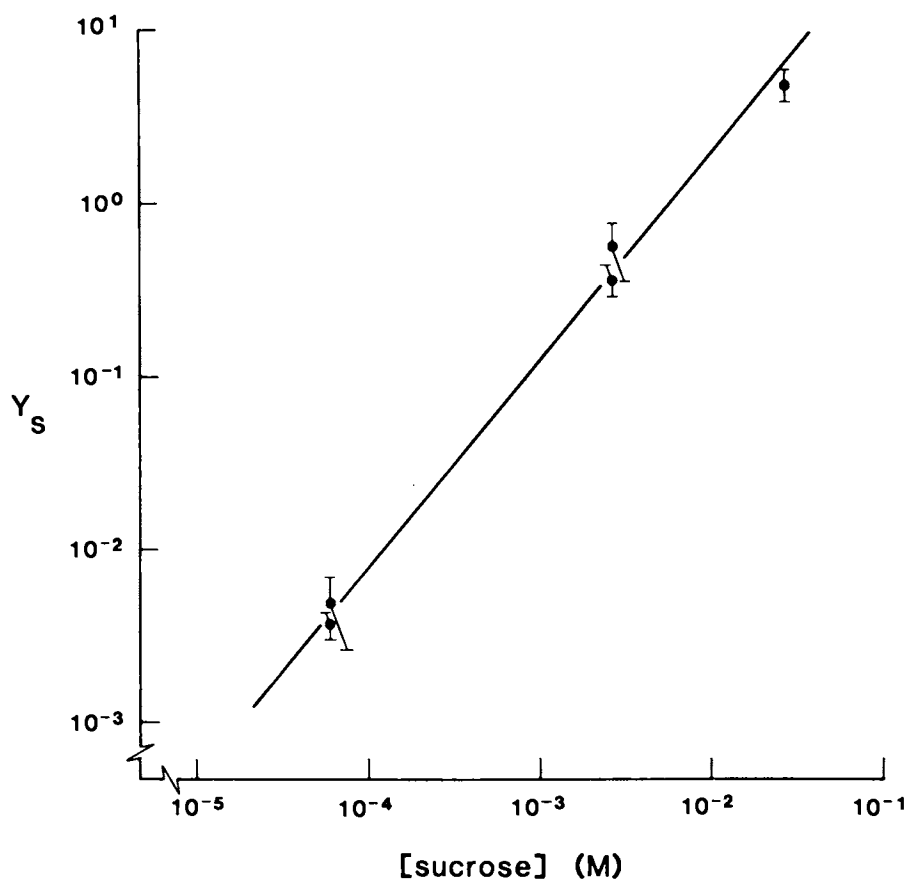


Figure 5. Total particle yields of sucrose versus sucrose concentration in glycerol: In-LMI source.

as those for pure glycerol. The yields for both the pure material and the solutions are nonlinearly increasing functions of energy. Sucrose yield as a function of solution concentration, Figure 5, is essentially linear over the range studied. Positive and negative secondary ionization efficiencies of sucrose were estimated from cursory ion yield measurements to be about 1×10^{-5} and 4×10^{-4} respectively. Results similar to those for sucrose were obtained for the $(M+1)^+$ ion of adenosine.

Analytical applications

This author and his associates initiated their work with LMI emitters to determine if they would be useful in fundamental investigations of secondary ion emission from liquid organic matrices. As a result, the initial experiments with LMI sources were performed on samples dissolved in glycerol in the same manner as is commonly done for FAB. Unusually high signals for the molecular ions of the sample compounds were immediately noted in these experiments (24,25,27). For example, the abundance of the $(M + Na)^+$ ion of stachyose produced from a glycerol matrix by bombardment with gold ions was found to be about 50 times that produced with a neutral argon beam and about 15 times that produced with a neutral xenon beam; the energies and current densities at the target were comparable for all of the primary beams.

The large gain in molecular ion abundance obtained by changing from a primary beam of argon atoms to one of gold ions cannot be explained on strictly theoretical grounds and may be partially due to differences in mounting the primary sources (27). Regardless of its explanation, it demonstrates that alternate primary source conditions exist which can significantly increase the sensitivity in SIMS of compounds in liquid organic solutions. Examples which demonstrate the potential utility of this increased sensitivity have been published elsewhere (24,25,27).

Because of its point source characteristic, the LMI emitter is particularly well suited to producing finely focused beams. It may be possible to take advantage of this focusing characteristic to increase the sensitivity of SIMS for organic compounds. Focusing the primary beam to a very small spot on the sample target can, with the proper source geometry, reduce the area which must be covered by sample. This could be taken advantage of to significantly reduce the actual amount of sample required for mass analysis and, consequently, achieve an increase in analytical (not just instrumental) sensitivity. Because neutral atom beams cannot be focused, it would not be possible to implement this method of increasing sensitivity with FAB sources. In this respect an ion beam is superior to an atom beam.

Chiat and Field (33) have recently investigated the use of a focused, pulsed LMI source in combination with a time-of-flight mass spectrometer for increasing the sensitivity of analyses by static SIMS. Their preliminary results are noteworthy. Using a primary beam focused to 100 μm diameter and average ion current densities of 0.6-60 nA/cm^2 at the target, they were able to obtain useful molecular weight information from as little as 1×10^{-15} mole of crystal violet and 3×10^{-12} mole of leucine-enkephalin, a neuropeptide. Actually, only 6% of the total sample introduced

into the mass spectrometer was bombarded by the primary beam indicating that the mass spectral information was being obtained on just 6×10^{-17} mole and 2×10^{-13} mole respectively of these two compounds. These investigators concluded from there findings that substantial improvement in sensitivity can be obtained by applying sample only to the area struck by the primary beam and that the inherent limitation in sensitivity by this method will arise in practice from an inability to handle very small amounts of material cleanly.

Stoll, et al (36) recently reported the operation of an ion microprobe that indirectly demonstrated the potential for higher sensitivity in the dynamic SIMS mode when a finely focused primary ion beam is employed. The ion microprobe consisted of a focused LMI source, capable of producing a beam spot $\leq 1 \mu\text{m}$ and an ion current density on the order of 1 A/cm^2 at the target, attached to a high resolution double focusing mass spectrometer (VG ZAB-2F) (37). To maintain both optimum acceptance of the mass spectrometer and spatial resolution of the primary ion beam over a relatively large field of view ($6 \text{ mm} \times 6 \text{ mm}$), two, high-precision, piezoelectric linear motors were used to move the sample probe in a X-Y plane perpendicular to the incident primary ion beam without deflecting the latter. This system was used to image a fine Ni-wire mesh (500 mesh, $25 \mu\text{m}$ wire diameter) with secondary ions of various organic compounds which had been deposited on the mesh; for example, a molecular image of the mesh was produced with a Fomblin ion at 1281 Daltons. Because of the very small beam dimension, the molecular weight of the imaging ion, and the use of a magnetic sector instrument, this experiment indirectly indicates a high sensitivity. It suggests that only a very small absolute amount of liquid sample solution would be required for analysis with this instrument.

Although only limited results have been reported to date, LMI sources do appear to have potential for practical, analytical applications in SIMS of organic compounds.

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Fast Atom Bombardment Mass Spectrometric Technique and Ion Guns

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The FABMS (Fast Atom Bombardment Mass Spectrometry) technique is reviewed in this chapter with emphasis upon laboratory instrumentation and procedures. Several popularly used primary beam guns are described including the effects of the bombarding species. Illustrative equations relating secondary ion currents to the primary impingement rates are presented. Geometrical arrangements between the primary beam, the sample target surface and the analyzer axis are illustrated. Solutions are suggested to overcoming limitations encountered in retrofitting FAB on mass spectrometers. Testing procedures are outlined along with matrix considerations. Sources of noise generated during particle impingement are examined. Some new experimental techniques are discussed which lead to increasing signal-to-noise ratios. Finally, SIMS (Secondary Ion Mass Spectrometry) is shown to be available to spectrometrists who have FABMS.

Background

Although the FABMS (Fast Atom Bombardment Mass Spectrometry) technique has only been in use for a few short years (since 1981), it traces its roots back well over a century (1). It has been observed that the bombardment of a surface by energetic ions produces the desorption of atoms and molecules from the surface of the target. This process, known as Sputtering, produces a yield (number of atoms sputtered per incident ion) which generally increases with the energy, the mass and the incidence angle of bombardment (2).

Only a small fraction, perhaps 1 percent of the sputtered particles, were found to be charged (3). Both positive and negative charges were found, depending upon the target materials. When mass analysis was applied to the process, it was then known as Secondary Ion Mass Spectrometry (SIMS). Subsequently, SIMS has been an important aid in investigating the surface material, the underlying composition can also be analyzed, leading to the technique of depth profiling. Methods were developed to deposit organic samples on

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surfaces which were then subjected to SIMS. This was known as Organic SIMS or Molecular SIMS, and became interesting to biochemists (3-5). Non-volatile organic samples can be analysed using this technique. However, this method suffers from short sample lifetime. When a sample exists as a monolayer, one is limited to about 10^{12} molecules on a typical spectrometer target area. Thus low bombarding ion current densities were required to extend the lifetime, but this in turn resulted in low signals (1, 6).

An innovation introduced by Barber and colleagues (7-9) allowed the observation of non-volatile and thermally labile molecules with adequate sample lifetime. The sample compound, dissolved in glycerol, was placed on a probe tip and introduced into the spectrometer. Bombardment by fast neutral atoms produced desorbed molecular ions with some fragmentation spectra. Fast atoms were chosen because they were not slowed or deflected by the positive voltage on the ionization source of the magnetic sector mass spectrometer used on these first tests and they avoided charging of the sample target. Although this technique became known as Fast Atom Bombardment Mass Spectrometry (FABMS), the new innovation was the use of the liquid matrix to contain the sample. Well known in the earlier sputtering and SIMS research, charging was not a problem and fast ions perform equally well as fast atoms (1, 10, 11). Other names, such as Liquid SIMS have been suggested for this process, but so far FABMS, a misnomer, remains rooted. FABMS should be defined as a process of atom and/or ion bombardment of a liquid containing a sample compound dissolved or floating in order to desorb molecular ions for analysis with a mass spectrometer.

Guns That Produce the Primary Beams

Several guns have been used to produce the primary beam to bombard the FABMS target (12). These beams are composed of fast neutral atoms or ions, or a mixture of the two. It does not appear that the charge state is critical, because desorption is produced by momentum transfer. Some of the guns and the characteristics of the beams are examined in this section.

The Saddle-Field Gun The Saddle-Field Gun, capable of producing both fast atoms and ions, was first commercially introduced for FABMS analysis (7, 13). Electron oscillations are induced in the gun chamber by electrostatic fields applied between the positive anode and the negative (grounded) cathode as seen in Figure 1. Electrons accelerated from the cathode region toward the anode, pass through the central openings because of the field configuration. Upon approaching the cathode on the other side, they are slowed, then return toward the anode again to repeat the reverse trajectory. Ions are generated by electron impact upon the gas atoms introduced into the gun chamber, thus forming a plasma in which new electrons are generated. Ions accelerated toward the upper anode can pass through the aperture to form an ion beam. The beam current is controlled by varying the voltage and/or the gas flow. Fast atoms are believed to arise when the fast ions capture an electron during an ion-electron collision (13). Because of the more favorable collision cross sections, it appears more probable that fast atoms arise from ion-atom charge transfer collisions.

The Capillaritron The Capillaritron ion source (Figure 2) consists of a fine bore (25 μ m) capillary nozzle and a concentric extractor electrode (14-16). By flowing a gas or vapor through the capillary, a microdischarge or plasma is formed at the exit orifice when a voltage (> 2kV) is applied between the capillary and the grounded extractor electrode. The small dimensions of the capillary orifice and overall nozzle shape are important factors in the initiation and stability of the plasma and subsequent ion/atom beam. These small dimensions allow guns to be designed to accommodate tight areas such as in the case of the DIP Gun. Ions generated by the plasma are accelerated by the electric field at the nozzle tip to form a beam. Some of the ions, when colliding with gas atoms emerging from the orifice, are neutralized by charge transfer and so become fast atoms. These fast atoms compose approximately half of the energetic beam (15). The beam current is also controlled by the voltage and gas flow rate. Typically xenon is recommended as the gas feed into the gun because of its high mass, but argon or virtually any other gas can produce FAB spectra.

The Cesium Ion Gun The Cesium Gun was introduced as a FABMS gun because the ion mass is large, close to that of xenon, and because it does not produce a gas load (17). Gas fed guns produce a gas load which degrades spectra on spectrometers having insufficient pumping speed. Operation of this gun can be explained with the help of Figure 3. Ions are thermionically emitted from the alkali aluminosilicate solid maintained at a high temperature (~ 1000°C) where the alkali species have relatively free movement. Upon desorption from the surface the ions are accelerated by the electric fields applied between the emitter and the accel or grounded electrode. Total emission current from the heated emitter surface is a strong function of the temperature. Virtually no fast or slow atoms are present and the ion beam energy distribution is very narrow. This narrow energy spread with the help of the lens shown in the figure, allows for beam focusing which is not readily available with some of the gas sources. The Cesium Gun has been reported to produce cleaner spectra with lower noise than the gas-type gun (18).

Other Primary Beam Guns The Liquid Metal Ionization (LMI) source, also a non-gas-fed source, operates on the principle of producing a cone-like apex on the surface of a liquid metal exposed to an intense electric field. At the liquid cone apex, the fields are sufficiently high (> 10⁹V/m) to extract ions by a field emission process. In order to produce the high fields required for ion emission using moderate extraction voltages (< 10kV), sharp, pointed emitters wetted by a liquid metal are generally employed. Molecular SIMS studies were made using a liquid metal ion source (19).

Radioactive fission products travelling with very high energies (MeV) have also been used to desorb molecular ions from a surface (20).

Effects of Primary Beam Species Prediction of FABMS source sputtering yields can be generally supported by available data on secondary ion emission coefficients. For secondary ions detected at zero angle with respect to the surface normal, the secondary ion emission yield generally increases with the mass of the primary ions because of the

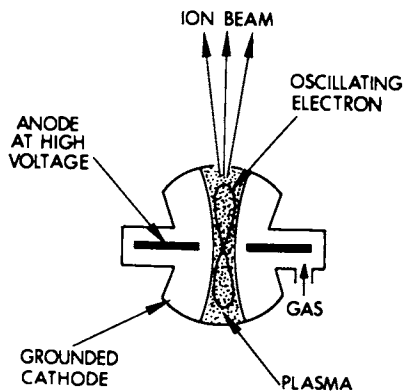


Figure 1. Saddle Field Ion/Atom Gun.

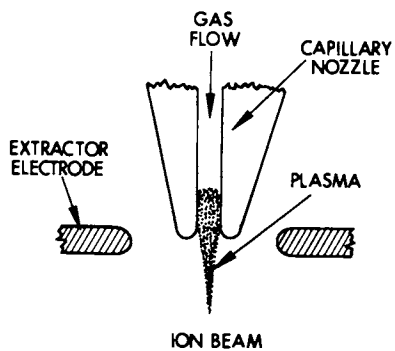


Figure 2. Capillaritron Ion/atom Gun

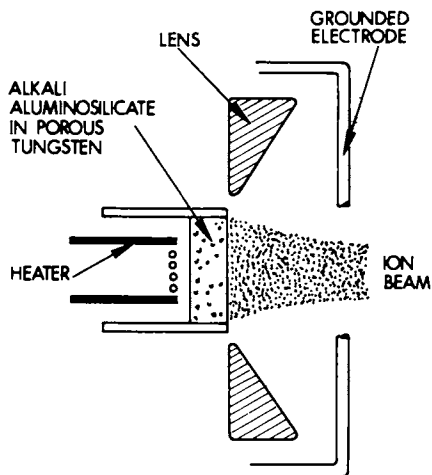


Figure 3. Cesium Ion Gun

increased momentum transfer during the ion-target collisions. Argon (40 amu) is often used as the primary beam gas because of its availability and low cost. Increased secondary ion yields were observed under xenon (131 amu) atom/ion bombardment (21) which led to other approaches such as non-gas-fed sources using cesium ions (133 amu) with a mass closely matching that of xenon. Further efforts to increase the mass of the bombarding species has seen the use of a mercury (200 amu) ion beam obtained using a saddle-field ion source (22). Mercury represents one of the high mass atomic ions generated by conventional ion sources and was reported to produce an enhancement of the secondary ion signal. An attempt to exceed the mass limitation imposed by monatomic elements has resulted in FABMS studies involving molecular ions (23). Siloxane (diffusion pump fluid) used with a saddle-field ion source, similar to the mercury investigations, produced 531 amu ions whose bombardment gave a reported enhancement in the secondary ion yield.

Recent developments with the LMI source show promising results for increasing secondary ion abundances (19). The primary ion species investigated were of the type M_n^{z+} where $M = \text{Ga}, \text{In}, \text{SiAu}$ or Bi . Mass analysis of the beam composition of LMI sources reveal the presence of cluster and multiply-charged ions, in addition to the predominant M^+ ion. These complex multiply-charged species provide a means for increasing the bombardment energy without the need for high accelerating voltages and thereby increasing the secondary ion yield. Future approaches may see FABMS guns which bombard organic sample surfaces by charged glycerol clusters in the range of 10Å ($\sim 10^5$ amu) to 100Å droplets ($\sim 10^8$ amu).

Although it is clear from the above discussion that increased mass of the primary ion species leads to high yields, nearly any ion could be used. Successful FABMS spectra were obtained using nitrogen gas when inert gases were not available for the Capillaritron. Even when gas from a tank is not available, which has occurred at trade show exhibitions, air from the room was used to obtain good spectra as seen in Figure (4).

Primary Ion Flux Desorption rates increase with higher primary ion flux rates until saturation effects set in. Saturation may be due to depletion of sample, loss of matrix or replenishment not keeping up to the desorption rate.

Assume the primary ion current leaving the gun is in the range of one microampere. After travelling a distance of 10cm the current density (j) is about $1\mu\text{A}/\text{cm}^2$ when the spread is about 5° . If the target area (a) is 5mm^2 then the primary ion beam (i) bombarding the target is given by

$$i = ja = \frac{(10^{-6}\text{A})(0.05\text{cm}^2)}{\text{cm}^2} = 5 \times 10^{-8}\text{A} \quad (1)$$

The number of primary ions per second (n) bombarding the target is

$$n = \frac{i}{e} = \frac{5 \times 10^{-8}\text{A}}{1.6 \times 10^{-19}\text{coul}} = 3.125 \times 10^{11} \frac{\text{part}}{\text{sec}} \quad (2)$$

where $e = 1.6 \times 10^{-19}$ coul the ionic (or electronic) charge. Typically the yield of secondary ions (Y), defined as the ratio of secondary to primary ion current is about 1 percent. The secondary ion current (I) is then

$$I = iY = 5 \times 10^{-8} \times 0.01 = 5 \times 10^{-10} \text{A} \quad (3)$$

or 3.125×10^9 ions/sec .

Generally, the secondary ion current desorbed from a surface, bombarded by the primary ions, is composed of various masses that can be resolved by the analyzer. We will instead assume the sample is a single mass of 100 amu. Consider a 100 nanogram of sample mass (m) dissolved in a glycerol matrix of $\frac{1}{2} \mu\text{l}$ and placed on the target. The total number of sample particles (N) is given by

$$N = \frac{m N_o}{M} = \frac{10^{-7} \cdot 6.023 \times 10^{23}}{100} = 6 \times 10^{14} \text{ particles} \quad (4)$$

where m is the sample mass, N_o is Avagadro's number 6.023×10^{23} particles per mole and M is the molecular weight of the sample in grams/mole, or 100 amu in this example.

If the sample is uniformly dispersed in the glycerol with a density of 1.26, then there would be one sample molecule for every 6900 glycerol molecules. The FABMS process demonstrates a much higher ratio of sputtered sample ions to glycerol ions, otherwise the signal would be totally lost in the glycerol signal (noise). This leads to the belief that a sample amenable to FABMS analysis probably resides mostly on the glycerol surface. This is also seen in data showing sample depletion with time accompanied by an increase in the glycerol peaks.

Geometry and Mass Spectrometer Limitations

Under consideration is the geometry of the target surface in relation to the incident primary beam and the direction to the analyzer. This will be followed by an examination of limitations found on mass spectrometers along with solutions and suggestions to aid in converting to FABMS.

Geometrical Arrangements To arrange appropriate and/or optimal conditions for secondary ion emission yield, the geometrical angles will first be defined.

Figure 5 shows the incident primary beam impinging upon the target containing a liquid or solid sample. Angle of primary ion incidence upon the target surface is conventionally defined with respect to the surface normal. The figure illustrates the typical FABMS arrangement. The ion gun producing the primary beam is often at an angle of 90° with the axis of the apertures to the analyzer. The sample at the tip of the probe is introduced into the ion source using the vacuum lock inlet. When the target is rotatable about the axis perpendicular to the figure, the angle of incidence (θ) can be varied. This also varies the angle to the analyzer (ϕ) since these two angles are complementary ($\theta + \phi = 90^\circ$). It has been found that

the spectral maximum has an optimum value when $\theta = 64^\circ$ (21, 25, 26). For some spectrometers it is not possible to rotate the target about that axis because of the position of the vacuum inlet, but it is possible to attain this optimal angular arrangement. Figure 6 is a three dimensional diagram showing the primary beam and the analyzer at 90° from each other and three different target tip configurations appropriate for different inlets. Tip shapes on each of the targets that achieve the optimum angle discussed above are depicted. Figure 7 shows a cross-sectional view of the target surface and how each probe type fits the arrangement initially illustrated in Figure 6. Each target has the same surface in common but enters along a different axis. If the vacuum inlet is not along a major axis, the target angle can still be made to fit the optimal angle. Similar configurations can be analyzed even if the primary beam and the analyzer do not make an angle of 90° . Of all the possible difficulties encountered in converting to FABMS capability, it is the vacuum probe inlet that makes conversion possible and is the only absolute requirement.

Pressure Problems Many of the older and some of the new smaller mass spectrometers have relatively low pumping capacity. Often there is no differential pumping to minimize the source load on the analyzer chamber. Extra pumps have been successfully added to spectrometers but this requires a major alteration to the spectrometer manifold. The gas guns described previously produce a gas load such that the operational pressure can exceed 10^{-4} torr. This will degrade the spectra by decreasing the signal, especially for the higher mass peaks. Figure 8 shows the peak size of two PFTBA mass peaks as a function of pressure. The excess pressure was due to xenon gas bled into the entire chamber of a benchtop mass spectrometer, including the source and the analyzer. The pressure data was not corrected for xenon but was made with an ionization gauge calibrated for nitrogen. To correct the pressure these values should be divided by a factor of 2.5. It would be desirable to operate below 10^{-4} torr and preferably 6×10^{-5} torr or lower as seen on the curves. Never the less FABMS spectra can be taken at 2×10^{-4} torr, as shown in Figure 9 (27).

FABMS can be accomplished on spectrometers having low pumping speeds, using the Cesium Ion Gun. This gun causes no gas load and produces virtually no neutral atoms as discussed previously. The gun should be kept at a reasonable distance from the ionization source to avoid heating which can limit the sample lifetime.

Flange Port Difficulties Several mass spectrometer types in use have non-standard flanges for mounting the FABMS gun. Some do not have conflat configurations and other flange ports are just too small. Both difficulties can be solved using a flange adapter having a conventional mating flange at one end to fit the gun and the match to the spectrometer flange at the other end. Generally the gun fits inside this adapter. In some cases this puts the gun far from the source resulting in low beam current densities at the target. It is less of a problem with the Cesium Gun because it is more amenable to focusing, which is not readily available to the gas guns. A second solution is the use of the MiniFACS gun. Designed to fit small flange openings, this gun configuration brings the ion

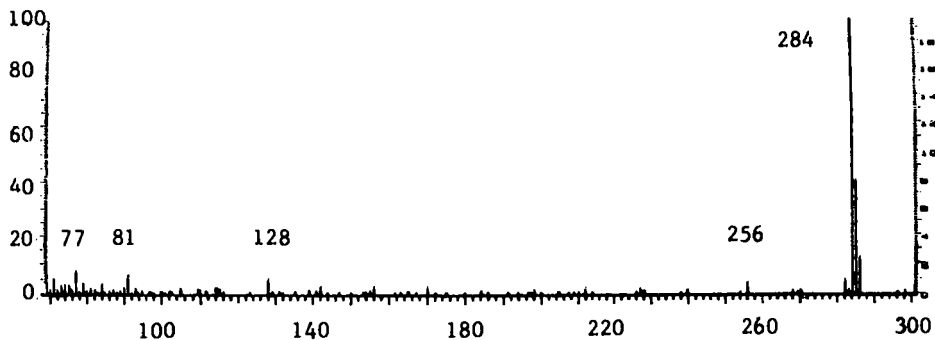


Figure 4. Spectrum of cetats [Hexadecyl trinethyl ammonium *para*-toluene sulphate $\text{CH}_3(\text{CH}_2)_{15}\text{N}^+(\text{CH}_3)_3$]. Taken during trade show using air for the primary beam.

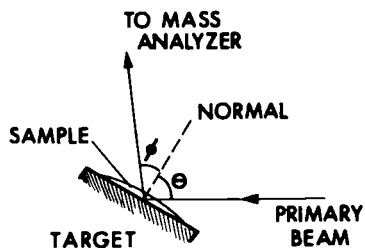


Figure 5. Diagram of the Incident Beam and Secondary Ions in relation with the Target

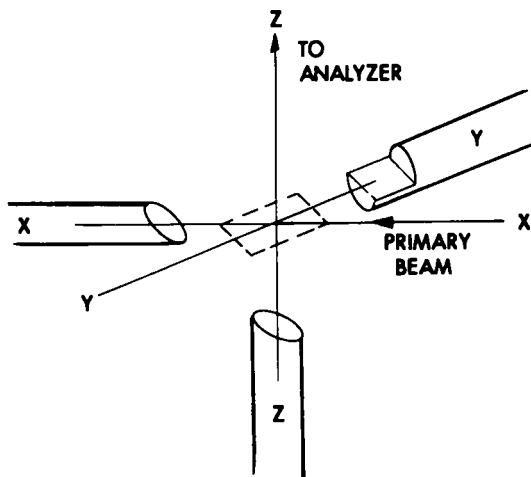


Figure 6. Several target configurations

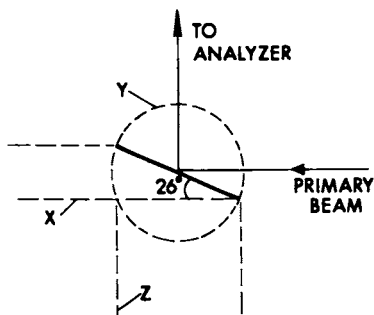


Figure 7. Optimum angular relationship at the FABMS target.

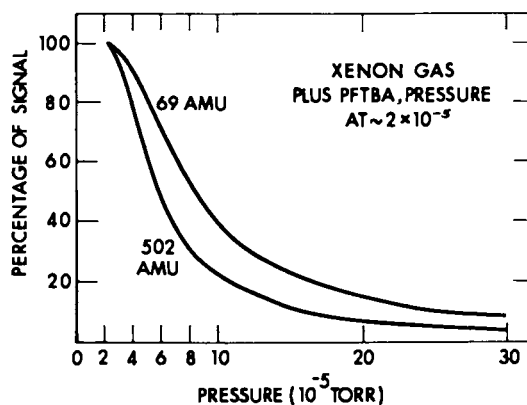


Figure 8. Decrease of signal with increasing pressure on an HP 5995 Bench-Top Mass Spectrometer.

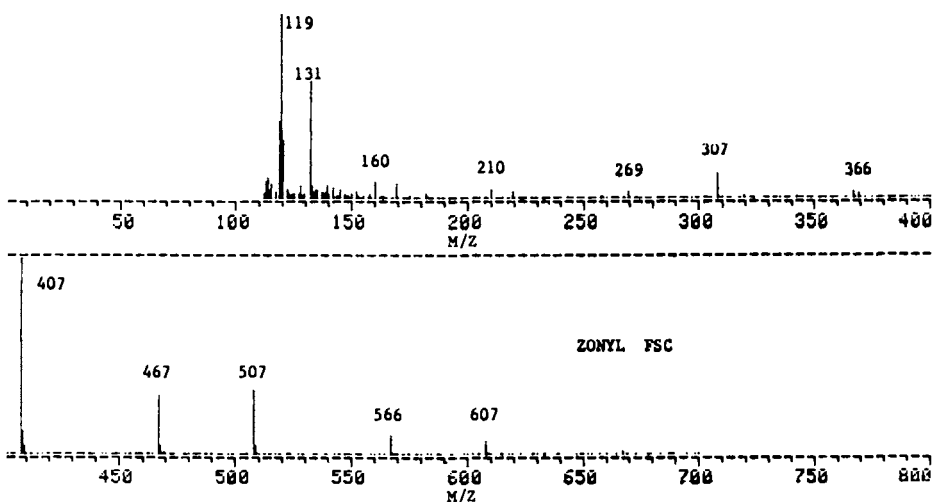


Figure 9. Spectrum of Zonyl FSC a fluorosurfactant $[R_f\text{CH}_2\text{CH}_2\text{SCH}_2\text{-CH}_2\text{N}^+(\text{CH}_3)_3\text{CH}_3\text{S}^-\text{O}_4]$ with $R_f = \text{F}(\text{CF}_2\text{CF}_2)_{3-8}$. Taken on an HP 5995 Bench-Top M.S.

beam generator to within 1cm of the aperture on the mass spectrometer ionization source. Thus high current densities are maintained even when operating at low current levels.

No Flange Port Available Some spectrometers have no flange port available for the FAB gun. Never the less a FABMS conversion can be made using the DIP Gun only if a vacuum inlet exists. The vacuum inlet must be larger than one-quarter inch in size, preferably one half-inch. DIP Guns have been made and tested having diameters of 11mm, 0.478 inches and $\frac{1}{2}$ inch. Of course the DIP Gun can be utilized and is even desirable if a spare vacuum port is available because it is simple to install and assures alignment between the gun and the target (28).

The DIP Gun is an insertion probe which contains both the ion gun and the target tip. This design, placing the ion generator at the end of a narrow probe, was made possible using the Capillaritron which has very small dimensions. Another benefit derived from the Capillaritron in the DIP Gun is that FABMS operation can be performed right after insertion and the gun can be removed immediately after because neither heating nor cooling is required.

The details of the configuration at the end of the DIP Gun designed for a quadrupole is illustrated in Figure 10. The nozzle tip, where the ion beam is generated, is located within and at the end of the probe shaft. The ion beam passes axially through the probe tip and impinges upon the target containing the sample. The target which is electrically grounded, has been designed for quadrupole mass spectrometers. An electrically insulated target, shown in Figure 11, is used with a magnetic sector mass spectrometer where ionization sources are operated at several kilovolts. In this latter design, the target holder contacts the ionization source block so as to attain the same voltage level. Because the Capillaritron generates fast ions and atoms, both equally capable of desorbing ions from the sample surface, fast atoms will impinge upon the target even when the gun voltage is lower than the ionization source voltage.

Special Gun Mounts The guns described above are mounted on flanges or or introduced through the vacuum lock. A few specialists have mounted the FABMS gun on the mass spectrometer ionization source structure with good results. These mounting procedures require careful planning and alterations of the source structure to assure alignment and minimal operational interference.

Rudat (29) has taken the nozzle from a Capillaritron gun and mounted it on his spectrometer source. Because of the small distance between gun and target, sufficient ion bombardment is attained at very low gun currents. Closely related to this work is that of McEwen who mounted a cesium gun on his ionization source (30). The gun functioned by using a filament to heat cesium chloride salts that drove off the cesium. Before emerging from the gun toward the target, cesium vapor is surface ionized by the filament, then accelerated by the impressed moltag.

A different type of cesium gun was mounted on the ionization source and compared with a conventional gas gun (10). This cesium gun operates on the principles described earlier. The more favorable results reported with the cesium gun test could be attributed in part to the better focusing performed with the cesium gun and the shorter

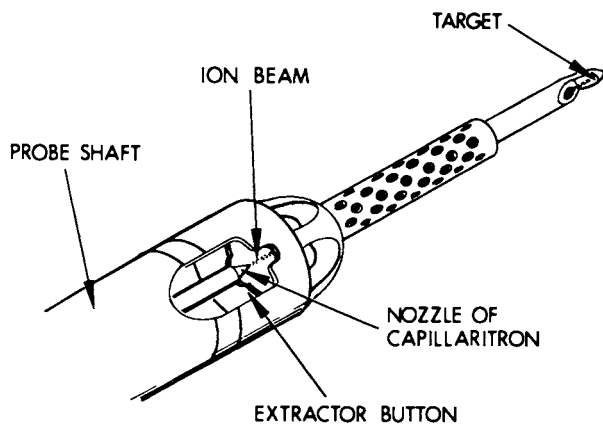


Figure 10. Dip Gun tip for a quadrupole mass spectrometer.

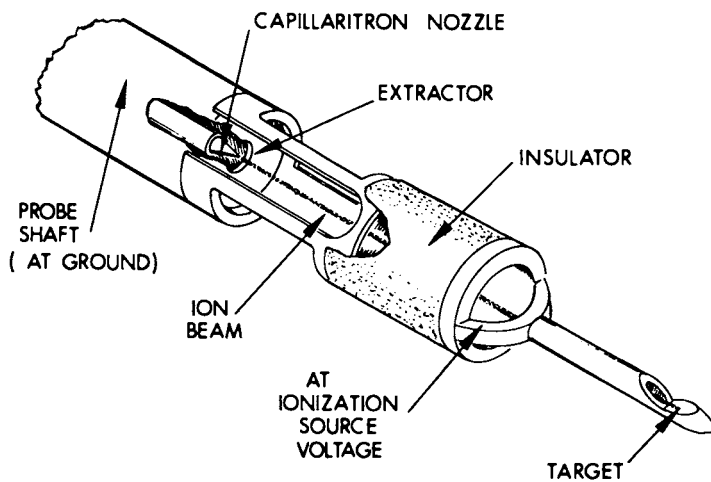


Figure 11. Dip Gun tip for a magnetic sector mass spectrometer.

distance to the target, in addition to other features of the cesium beam, discussed later.

Spectrometer Tests

Matrix Considerations Non-volatile and thermally fragile molecular samples are dissolved in a liquid matrix for introduction into the spectrometer to perform FABMS measurements. The properties generally imposed upon the matrix include: ability to dissolve samples and possession of low vapor pressure to extend life time in the vacuum environment. Sample life time should be several minutes to be able to optimize the spectral signal and make several spectral runs. Many organic liquids that satisfy these requirements have been used to obtain FAB data by several investigators (7, 31, 32). Two of the more often used matrices are glycerol and thioglycerol. In addition, a liquid metal matrix was used to float the sample to obtain FABMS spectra (33).

Glycerol, the most popular FABMS matrix, will be examined here. Consider a sample dissolved in glycerol and a droplet placed on the target. Assume a droplet volume of 0.5mm^3 with a density of 1.26g/cm^3 giving a mass of $6.3 \times 10^{-4}\text{g}$. The glycerol will evaporate in the vacuum at a rate which is strongly dependent upon the temperature. The evaporation rate, \dot{m} , in g/sec, is given by

$$\dot{m} \left(\frac{\text{g}}{\text{sec}} \right) = 5.833 \times 10^{-2} P \left(\frac{M}{T} \right)^{3/2} a$$

where P is the vapor pressure in torr, M is the molecular weight, T is the Kelvin temperature and "a" is the area in cm^2 . At 20°C the vapor pressure is $1.75 \times 10^{-4}\text{torr}$ and the evaporation rate is $2.9 \times 10^{-7}\text{g/sec}$ from a sample whose area is 5mm^2 . At this rate the glycerol would last 14 minutes and at 40°C only 5 minutes. At 100°C it would disappear in about 2 seconds. This illustrates the importance of maintaining a cooled target and source below 30°C . Heating transfer tubes and analyzers should be avoided. Data can be taken at higher temperatures, but the short lifetimes require excellent preparation and impose insufficient time for optimization.

The next question is: what is the effect of sputtering on sample lifetime? If we assume that the sputtering yield is unity and the current is $5 \times 10^{-8}\text{A}$, the sputtering rate would be $3 \times 10^{11}\text{part/sec}$ or $4.6 \times 10^{-11}\text{g/sec}$. This is over 6000 times lower than the evaporation rate at 20°C . Even if the yield were higher and the ion current raised, it is not likely that the sputtering rate would compete with evaporation. However, the ion bombardment can heat the sample and target structure, raise the temperature, and cause more rapid evaporation.

Ion bombardment of glycerol with sample dissolved can produce molecular ions and glycerol cluster ions. Field (34) studied the effects of bombarding a glycerol sample to study the products. Better molecular ion spectra were found to occur when acid or alkali salts were added (2).

Spectrometer Preparation To operate with sufficient sample lifetime, the ionization source and nearby components such as the transfer tube and exit slits should be cooled hours before initiating tests. This

is to assure that the source temperature is below 30° to produce sample lifetimes of over 10 minutes. The electron emitting filament used with EI must be turned off. In some cases it helps to optimize the spectrometer parameters to favor high mass sensitivity. Then it should be balanced over the mass range after appropriate high mass peaks are observed.

To assure that proper gun operation and alignment exist, the following testing procedure is suggested.

1. Turn on the FABMS Gun with no target in the source. The pressure in the source chamber will increase when a gas gun is used but show no effect with a cesium gun. The spectrum of the gas, be it xenon or argon, will be observed - or cesium from a cesium gun.
2. Insert the bare target into the source and turn on the ion gun. Spectra of the target material will be observed. This is actually a SIMS spectra. If the target material is stainless steel, the spectrum will show peaks in the 50 to 60 amu range for isotopes of iron and nickel. Optimize the position and angle of the target tip. Note that with the tip in place, the repeller voltage is generally ineffectual because of shielding. However, applying voltage to the target, if it is electrically isolated, can enhance the signal (26).
3. Place a droplet of glycerol on the target and insert the probe to observe the spectrum of the glycerol monomer, dimer, trimer, etc. and derivatives. Optimize the parameters to obtain strong peaks and minimum noise.
4. Dissolve a known sample in glycerol, place it on the target, insert and take the FAB spectrum. Compare the spectrum with published spectra and optimize the signals.
5. Then one is ready to measure an unknown sample with the knowledge that the FAB mode is in good operation.

This series of tests assures that: the gun is operating, the target is in place, glycerol is in the correct place, a known FAB spectrum is duplicated.

Noise When the spectral signals are low, FABMS spectra show a continuous background noise. A peak will show up at virtually each mass (32). This is thought to be caused by the very process of ion/atom bombardment. When the energetic ions/atoms strike the sample surface, momentum is transferred which causes the desorption of sputtered molecules and ions at perhaps a short distance away from the impact site. But right at the impact site, the collision causes fragmentation. Some of these fragments are charged and produce peaks all over the spectral range. In addition, fast ion/atoms are reflected off the various surfaces and into the analyzer region. A magnetic sector spectrometer will not allow the atoms to reach the detector because of the curved path and the ions do not have the correct energy to pass through the curved path to produce a signal. However, a quadrupole will transmit fast atoms and fast ions with no discrimination which produces noise. One would expect that xenon, more so than argon, would produce a lower noise level, or higher signal-to-noise ratio because fewer primary ions/atoms are required to produce a comparable signal. Cesium ions were found to be even more favorable in producing low noise on a quadrupole, as discussed previously and shown in Figure 12 (18). Much of the noise is attributed to fast atoms which are thought to undergo primary scattering and more readily pass through the analyzer.

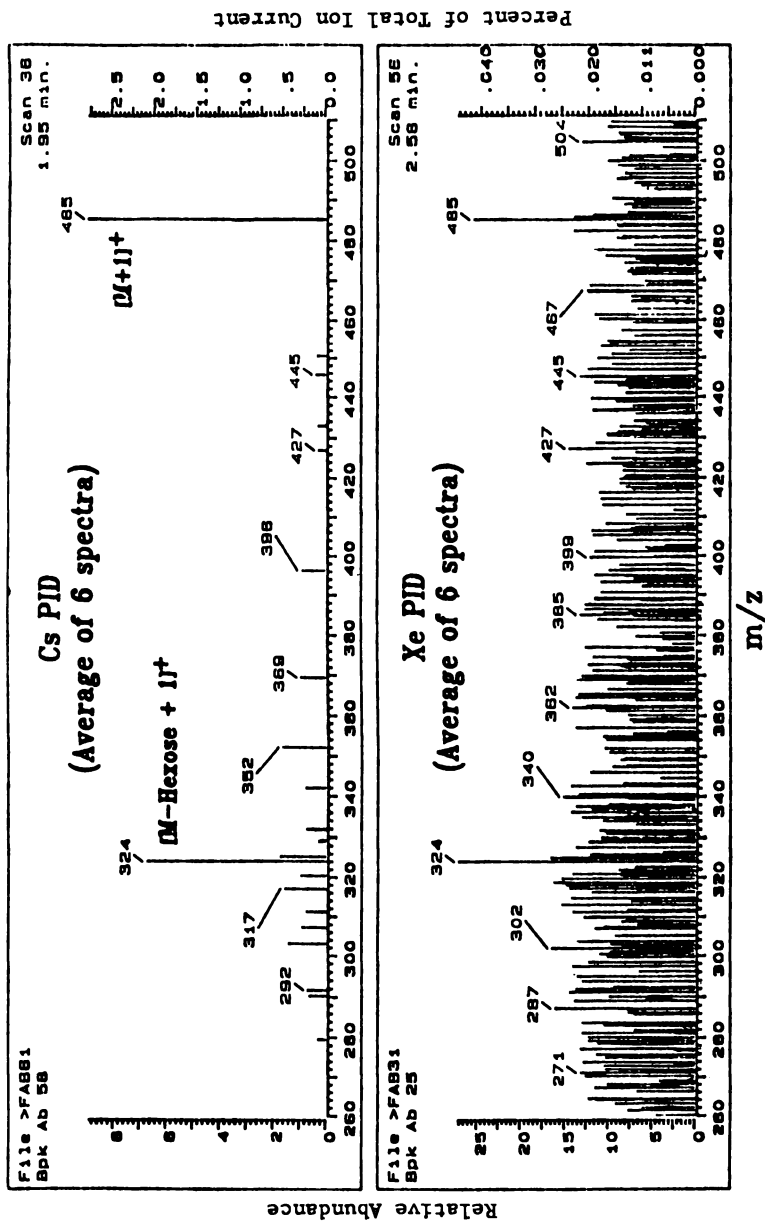


Figure 12. Spectrum of Kanamycin taken on an HP 5985 comparing a cesium with a xenon primary

Some New and Old Techniques

In considering the many possible arrangements of gun, target and analyzer, the direction most avoided is "in-line". When the primary beam is fired in line with the analyzer, the beam ions contribute greatly to the noise background without even being scattered. However, two successful examples of near-in-line mounting are described here.

DIP Gun In-Line on a Quadrupole A standard DIP Gun, described above, was fitted with a special tip for testing on a Finnigan 4500 Mass Spectrometer which has the vacuum lock inlet in line with the quadrupole analyzer. Requirements are imposed that the primary beam not impinge directly on the analyzer entrance apertures and that the secondary ions leaving the target be directed toward the analyzer. Figure 13 shows a configuration that satisfies these requirements. The ion beam leaving the Capillaritron nozzle is deflected downward, by the proximity of the Extractor Tab, into the tip Cylinder. The Target at the end of the tip contains the sample. Bombardment of the sample at the grazing angle of incidence enhances the production of slow molecular ions and also produces fast scattered ions/atoms. A positive potential on the Shield/Repeller provides the field to repel slow ions toward the analyzer while they are attracted toward the Draw Out electrode. The Shield/Repeller also is the barrier preventing primary ions/atoms from traveling directly toward the analyzer. This general configuration without the voltage on the Shield/Repeller and the deflector tab was tested using a DIP Gun on a 4500 and produced suitable spectra shown in Figure 14 (35, 36).

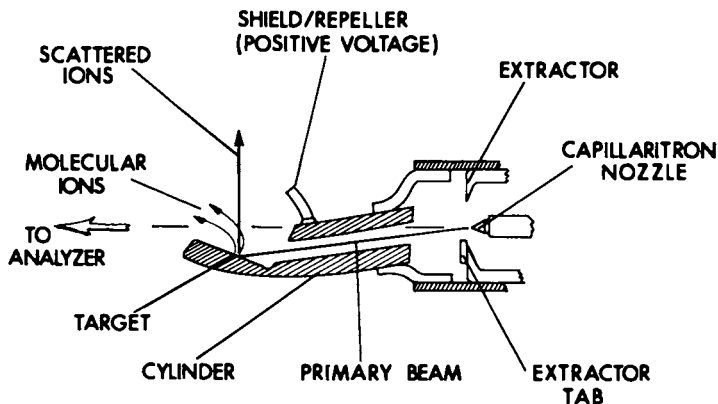


Figure 13. DIP Gun tip for an inline vacuum lock inlet.

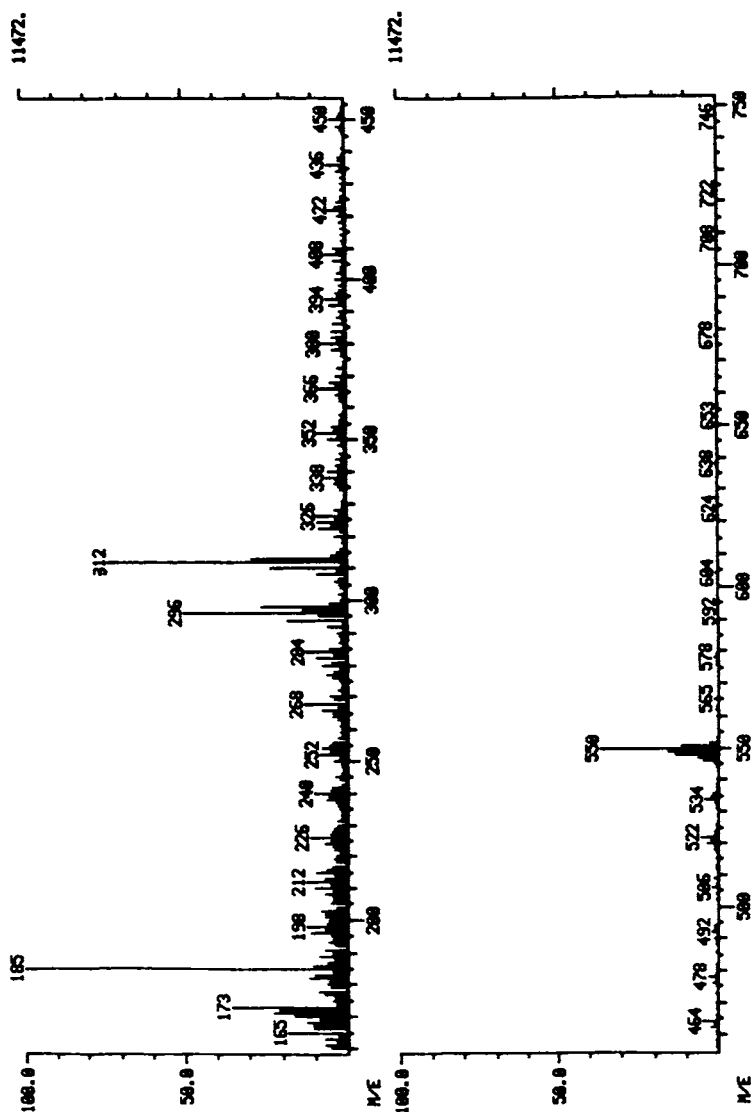


Figure 14. Spectrum of Dimethyl octadecyl ammonium chloride $[(\text{CH}_3(\text{CH}_2)_{17})_2\text{N}^+(\text{CH}_3)_2]$. Taken on a Finnigan 4500 using a Dip Gun with the inline configuration.

Cesium Gun In-Line on a Magnetic Sector A cesium gun was mounted in the source manifold oriented so that the ion beam just misses the entrance aperture of an MS-50 (37). The target, coated with sample, is the inside of a truncated cone. The grazing angle of incidence was also advantageous in producing more secondary ions.

Lowering Noise Levels Techniques to lower the noise level due to ion/atom scattering are being investigated. The DIP Gun target is oriented to face the analyzer, described before, which is the configuration found to maximize the secondary ion signals. But it also results in intense ions/atoms scattering toward the analyzer. The DIP Gun can be rotated to decrease the noise due to scattering. Figure 15 shows the target tip facing the analyzer (0°) and rotated through 90° and 180° . At 90° few ions/atoms are directly scattered toward the analyzer. At 180° no ions/atoms are scattered toward the analyzer. The noise level decreases markedly as the angle increases with a minimum at 180° . The signal level was found, under some conditions, not to vary appreciably since the slow moving secondary ions can be accelerated toward the analyzer by the repeller and draw out electrode. The signal-to-noise ratio was found to increase by a factor of 40 on a quadrupole mass spectrometer (35).

The second example employs the near grazing primary ion incident on the target which faces the analyzer entrance aperture of a magnetic sector. The scattered ions leave nearly parallel to the surface and the slow molecular ions are drawn out using an immersion lens (37).

Secondary Ion Mass Spectrometry SIMS preceded and laid much of the groundwork used in FABMS as discussed in the Background. To come full circle a FAB apparatus on a mass spectrometer can be used to

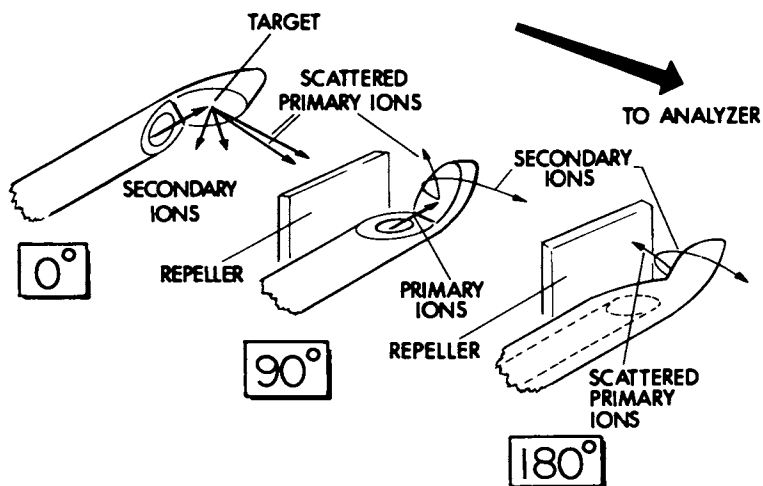


Figure 15. Dip Gun tip shown in three orientations of 0° , 90° , and 180° used to minimize FAB noise.

analyze surfaces of a wide range of materials, including the target or in the form of small samples. Both fast atoms and ions are capable of desorbing ions from virtually any solid surface. Similar to Organic SIMS, inorganic surfaces are analyzable. The target surface can be the sample as in the tests described previously to determine the sensitive position and orientation of the target by observing the SIMS spectra of the stainless steel target. Other materials in the form of foils, powders or fabrics can be cemented to the target and bombarded by the beam from the FABMS gun. Several metals and ceramics were analyzed by this method.

A tantalum foil was cut into a sample slightly smaller than the target stage. It was glued on with several different ordinary cements. The resultant spectrum revealed a wide range of tantalum and oxide molecules (clusters). These include three striking peaks of Ta, TaO and TaO₂ followed by a series of much smaller peaks, each separated by 16 amu. Also observed was Ta₂, Ta₂O, Ta₂O₂ and Ta₃, Ta₃O, Ta₃O₂ etc. These were clear single peaks because there is only one dominant isotope of tantalum. A molybdenum foil was also analyzed and this is shown in Figure 16. Molybdenum has seven dominant isotopes between 92 and 100 and the relative abundances seen in the spectrum is approximately equivalent to the isotope abundances. Another grouping with oxygen added is seen 16 amu above the first one, and a third with O₂ added is also observed. The Mo₂ group with the O and O₂ additions are also observable. Only slight evidence of the Mo₃ group is seen.

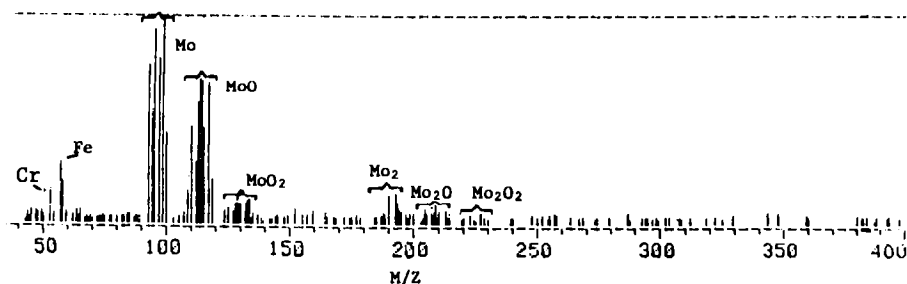


Figure 16. SIMS spectrum of a molybdenum foil taken on an HP 5995 Bench-Top MS.

Acknowledgment

The author wishes to acknowledge the help provided by John F. Mahoney in preparing this paper.

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Fast Atom Bombardment Secondary Ion Mass Spectrometric Surface Analysis

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Fast atom bombardment (FAB) secondary ion mass spectrometry (SIMS) permits the static and dynamic surface analysis of insulating materials without the severe charging effects experienced by ion beam bombardment. The relatively low potential surface charge which may accumulate on insulating materials during fast atom bombardment due to secondary ion and electron emission is readily neutralized by low energy photoelectrons produced by irradiation of the area adjacent to the sample with a small mercury discharge lamp located within the analysis chamber. Characteristics of the FAB gun and applications of the FAB SIMS technique to the analysis of polymer films and inorganic powders are described.

SIMS analysis of electrically insulating surfaces using a positive or negative ion beam requires surface charge neutralization in order to obtain useful secondary ion yields. This is most often accomplished by irradiating the surface under investigation with a 0.5 to 3 keV electron beam. This requires very careful adjustment of neutralizing beam parameters since any small residual charge on the specimen surface may affect both the secondary ion yield and the energy distribution of the secondary ions. In quadrupole mass analyzer based systems, slight surface charging often results in the secondary ion energy distribution shifting to values outside the band pass of the quadrupole prefilter. Under these conditions, a partial or total loss of signal occurs. In addition, as the specimen is eroded by sputtering, the work function and other surface characteristics change resulting in the need for more or less constant fine tuning of the neutralization parameters during surface analysis. Further, the added thermal and electrical effects of the electron beam can cause damage to fragile polymeric materials, it can result in unwanted electron beam stimulated surface desorption, and

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can cause migration or diffusion of alkali metals away from the surface.

The use of FAB probes to alleviate the problems associated with surface charging has been previously reported in literature (1-4). In general, these articles suggest that no external neutralization source is required with a neutral beam on insulators. This article will show where neutralization can be used to advantage and will describe results obtained with a simple scheme of neutralization utilizing photoelectrons ejected from the area surrounding the sample when irradiated by a small mercury discharge lamp within the analysis chamber. The use of FAB SIMS for the analysis of polymer surfaces and inorganic oxides will also be reported.

Experimental

FAB sources of various types are described in literature. The high "current" sources such as the Saddle Field (5) or Capillitron (6) which have recently come into use for bulk mass spectrometric analysis of involatile organic materials are generally not useful for "low-damage" surface analysis. The reason is because of the inability of these sources to obtain steady or reproducible atom flux at the low dose conditions, i.e., 10^{-6} to 10^{-10} A/cm² equivalent, required for the analysis of thermally sensitive materials. The source used in this study is shown in Figure 1 and consists of a commercial ion gun (Mini Beam - Kratos, Inc.) to which has been added a charge exchange chamber to neutralize the ions from the ion gun. Sources of this type have recently been described in literature (7-9). Since significant surface chemical differences between samples can be accompanied by only subtle intensity changes in molecular SIMS fragmentation patterns, emphasis was placed on designing a source which produced a stable and highly reproducible atom beam. The design shown permits precise measurement and control of the gas pressure in the ion source region and in the exchange chamber which are necessary requirements for reproducible operation. Figure 2 shows that for argon, the most efficient charge exchange occurs within a narrow pressure region centered at about 1.5×10^{-2} torr. The data show that the pressure at which the neutral flux is maximum is independent of the beam energy. This is due to the essentially constant charge exchange cross section for argon within this energy range. At pressures higher than optimum for neutralization, the neutral flux is reduced by scattering processes. At the optimum pressure, our measurements show that approximately one half of the ions are neutralized. The pressure in the ion source region is maintained at 1×10^{-4} torr and in the charge exchange chamber at 1.5×10^{-2} torr by automatic pressure controllers (Veeco APC/1000) which operate piezoelectric leak valves. When operated as an ion source (charge exchange chamber evacuated), the gun is capable of maximum argon ion current of 1.5 microamps at 5 keV at a spot size of about 2 mm. The maximum equivalent neutral flux as measured indirectly by secondary ion yields from neutral bombardment of a titanium metal target is approximately one half of the ion current.

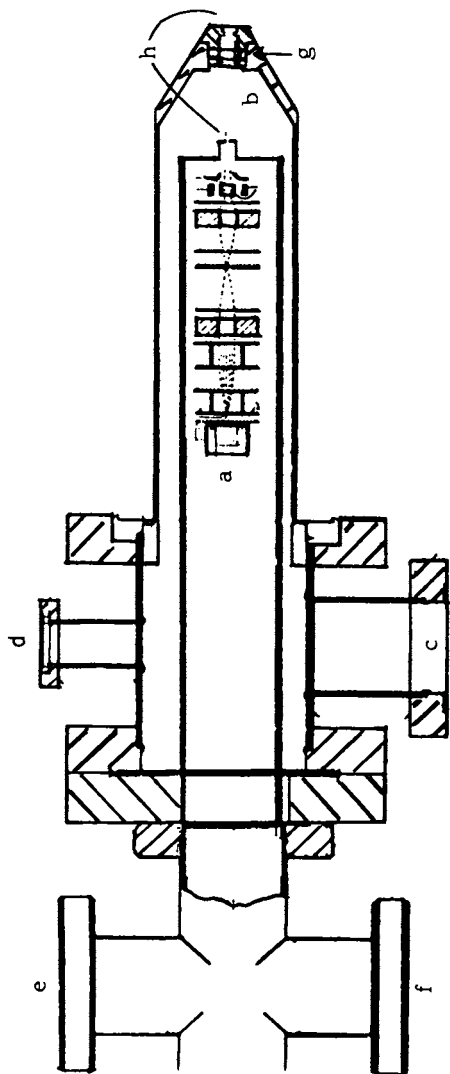


Figure 1. Fast Atom Bombardment Source

a. ion gun b. charge exchange region c. f. pumping ports
 d. exchange region gas admission port e. ion region gas
 admission g. deflection electrode h. 0.75 mm apertures

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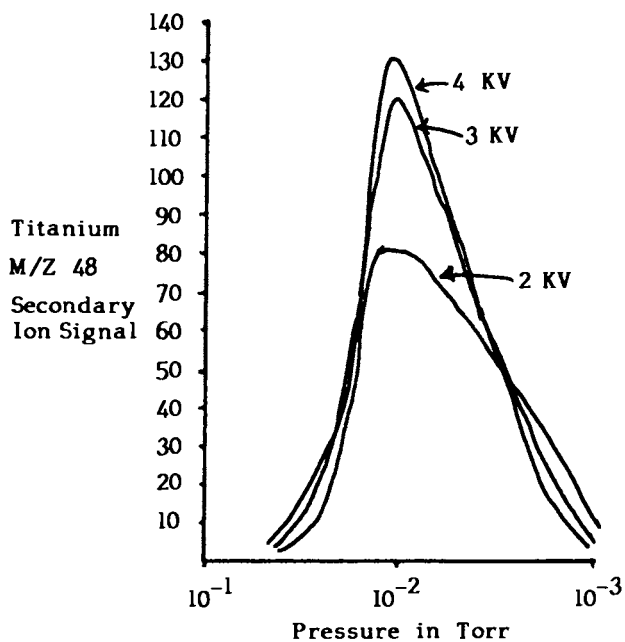


Figure 2. Argon Neutral Yield* vs. Charge Exchange Chamber Pressure

*As measured by secondary ion signal at M/Z 48 from titanium metal target

The secondary ion extraction optics and ion energy filter is of commercial design (Kratos). Also incorporated in the analysis chamber is a scanning electron gun having a 1 micron beam size which is used for imaging and positioning the specimen under the neutral beam. In most cases, the area where the FAB beam impinges upon the sample is visible by secondary electron imaging thus providing a convenient method of sample positioning. The charge neutralizer consists of a Series 81 Analamp mercury discharge lamp (BHK, Inc., Monrovia, CA), located within the analysis chamber approximately 7 cm from the specimen surface. The lamp is mounted on a 1 cm diameter copper bar which in turn is mounted on a chamber flange. This heat-sink mounting is required to prevent excessive pressure buildup in the lamp which causes an unstable discharge.

Results and Discussion

Charge Neutralization. When an insulator is bombarded with a beam of ions, the resultant surface charge will depend on the sum of the primary current and its potential, current from the emission of secondary ions and electrons, and tertiary currents representing miscellaneous contributions from scattered ions, neutrals, and electrons within the analysis chamber. When neutral particles are used for bombardment, the resultant surface charge will depend primarily on the sum of the secondary and tertiary currents. The surface potential buildup is thus much lower with a neutral beam than with an ion beam, and it is always possible to obtain a SIMS spectrum without any form of charge neutralization which is not the case when ion bombardment is used. Nevertheless, the charge effect with neutral bombardment can result in significant problems in SIMS analysis. Specifically, quadrupole mass spectrometers require that the secondary ion energy distribution be in a range generally below 20 eV in order to achieve efficient mass filtering. Although in principle one can decelerate secondary ions to below this potential; the difficulty with this approach is that the charge on the insulator is generally not maintained constant during analysis. This is particularly true of powdered materials, individual particles of which may achieve significantly different electrostatic charge. In addition, it is often advantageous to select a narrow energy band pass of secondary ions in order to differentiate between mass spectral interferences caused by molecular and atomic species (10). Under these conditions, changes or instabilities in the energy distribution of the secondary ions during the analysis will confuse the results.

Figure 3a shows a pattern of the FAB SIMS spectra of a photochromic glass. Molecular fragment ions are apparent from M/Z 60-70, and zirconium atomic fragment ions are observed at M/Z 90-96. No neutralization was used, and the band pass of the quadrupole prefilter was adjusted for maximum signal at 90 AMU. A direct measurement of the secondary ion energy

distribution was not made, but computer modeling of the prefilter characteristics suggests that under the conditions used, the band pass was centered at about 45 eV. Even though the quadrupole resolution setting was at its optimal value, the resolution of the spectrum is poor because of the high energy of the secondary ions. Figure 3b shows the spectrum of the same glass after turning on the mercury discharge lamp and readjusting the prefilter settings to again obtain maximum signal at 90 AMU. (The center of the prefilter band pass was estimated to be 7 volts.) The y intensity axis in both cases was the same.

The neutralization effect of the mercury lamp appears to be due to the ejection of low energy photoelectrons from the vacuum chamber walls and equipment contained therein. Focusing an external source of mercury radiation directly onto the sample surface (using UV transmitting optics) does not result in charge neutralization. However, when this external radiation is directed to a small piece of stainless steel immediately above and to the side of the sample, then neutralization takes place. Figure 4 shows the target current from photoelectrons, obtained with a conductive target, as the target potential is varied from 0 to +20 volts. Over one half of the available photoelectrons are collected at a target bias of 5 volts. This suggests that an insulating specimen surface which may charge to +45 volts during fast atom bombardment would be a very efficient collector of the photoelectrons. Considering the secondary and tertiary currents normally involved during analysis, it is likely that the surface potential of insulators remains at 5 volts or below because of the "self-regulating" effect of charge neutralization by this technique. Charge neutralization can also be accomplished by irradiating the sample with low energy electrons from a source such as a heated tungsten filament. This technique adds considerable thermal energy to the sample unless the source is designed to shield the sample from the infrared radiation of the filament. High energy electrons such as from an electron gun having rastering capabilities can also be used, however, this requires careful and continual adjustment because neutralization is not self-compensating, and slight surface changes result in over or under neutralization.

Figure 5 shows the effect of thermal damage on polyethylene when utilizing a 2 keV, 1 microamp electron beam for charge neutralization. "Carbonization" of the surface begins to take place within the first few seconds of analysis when the electron beam is used whereas with the mercury-lamp-photoelectron method, a stable spectrum is obtained for periods of several minutes.

During analysis using negative secondary ions, the extraction optics and quadrupole detector are biased in such a manner as to pass and detect electrons as well as negative ions. Figure 6a shows the spectrum of contaminated quartz from argon ion bombardment with electron gun (2 keV) charge neutralization, and Figure 6b shows a spectrum of the same sample with equivalent argon neutral beam bombardment and without charge neutralization. The difference in background counts shown at 45 AMU is about a factor of 30.

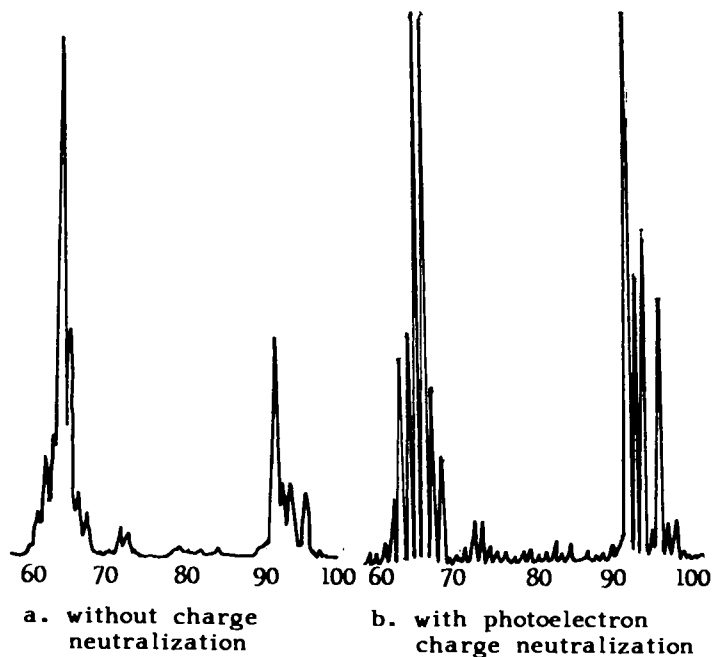


Figure 3. FAB SIMS Spectra of Photochromic Glass

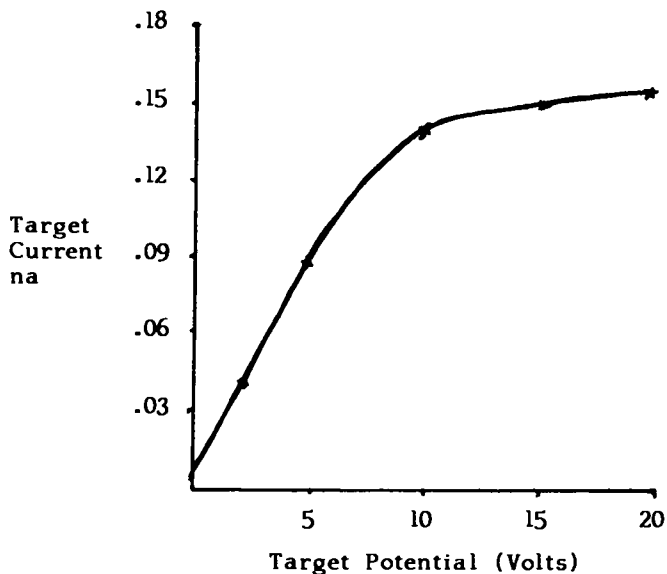


Figure 4. Target Current vs. Target Potential
Mercury Discharge Lamp Induced
Photoelectrons

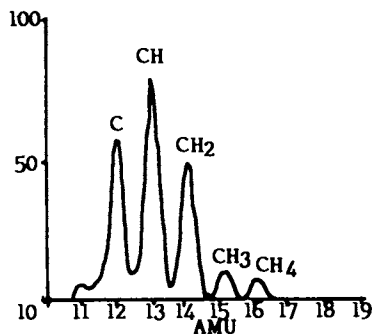


Figure 5a. First Spectrum, 10 sec Scan, e Beam Neutralization

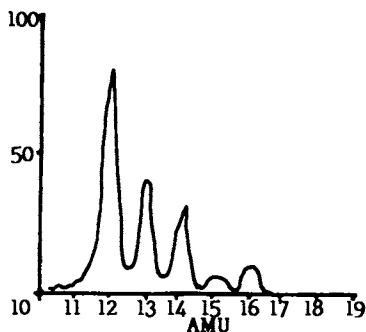


Figure 5b. 40th Spectrum, 400 sec, e Beam Neutralization

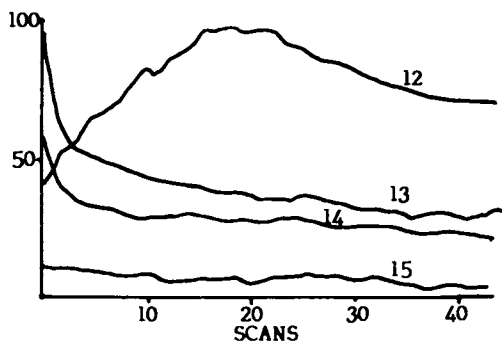


Figure 5c. Depth Profile of Polyethylene Surface - e Beam Neutralization

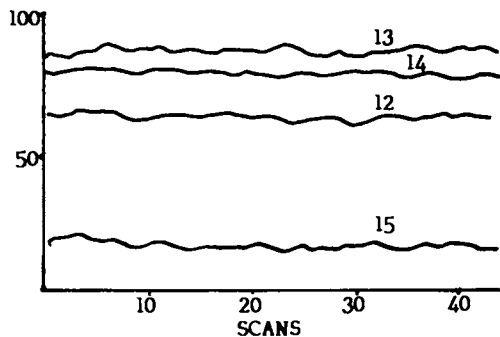


Figure 5d. Depth Profile of Polyethylene Surface - Mercury Radiation Induced Photoelectron Neutralization

Figure 5. FAB SIMS Spectra of Polyethylene Showing Thermal Damage with e Beam Charge Neutralization

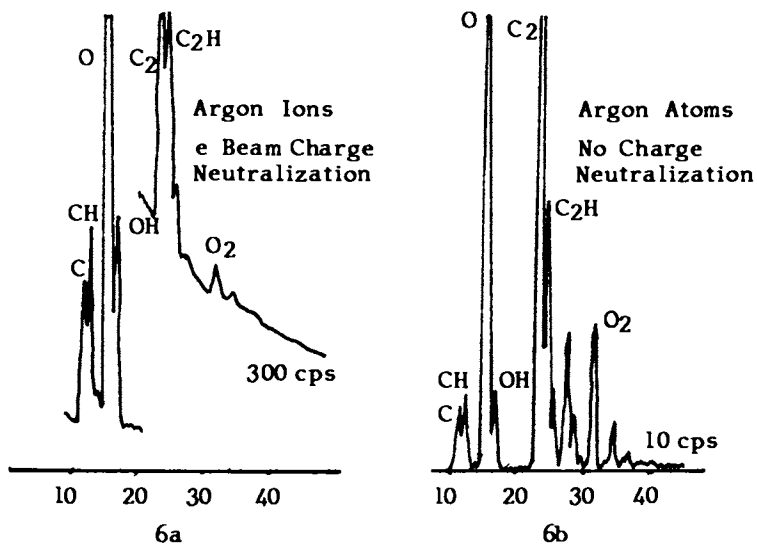


Figure 6. Negative SIMS Spectra of Contaminated Quartz

Cobalt Oxide Analysis. The magnetic characteristics of ferric oxide particles of the type used in magnetic recording media are often modified by surface treatments involving deposition of up to a few hundred angstroms of oxides of cobalt on the iron oxide particles. The cobalt oxidation state (oxide stoichiometry) is not readily determined on surfaces of this type by the more conventional techniques such as X-ray or electron diffraction or X-ray photoelectron spectroscopy (XPS or ESCA). These particles are thermally unstable and are electrical insulators. Initial attempts to differentiate the various oxides of cobalt with ion beam bombardment and electron beam charge neutralization were not successful. Table I shows the relative abundances of secondary ions from argon atom bombardment for the oxides and hydroxide of cobalt indicated. The data were normalized to the M/Z 59 intensity. Line 5 shows the average of the data shown in line 1 (CoO) and line 2 (Co₂O₃) and is what one might expect for an equal mixture of CoO and Co₂O₃ if the secondary ion yields were the same for both. This agrees well with the data for Co₃O₄ which can be thought of as CoO·Co₂O₃. The hydroxide spectrum is distinguished in particular by the large peak at M/Z 134. The negative ion spectrum of Co(OH)₂ also contains a parent peak at 77 which is not observed for the oxides. In addition, the hydroxide contains larger peaks at M/Z 33 (HO₂⁻) and 17 (OH⁻) than the cobalt oxides.

Table I. FAB SIMS Fragmentation of Cobalt Oxides

	Co ⁺ 59	CoO ⁺ 75	Co ₂ ⁺ 118	Co ₂ O ⁺ 134	Co ₂ O ₂ ⁺ 150
1. CoO	100	3.4	11.4	23	1.2
2. Co ₂ O ₃	100	1.9	11.0	14	0.2
3. Co ₃ O ₄	100	2.7	11.2	18	0.5
4. Co(OH) ₂	100	7.6	11.7	95	4
5. CoO + Co ₂ O ₃	100	2.6	11	18	0.7

Polymer Surface Analysis. The major technique used for the surface analysis of polymers has been X-ray photoelectron spectroscopy (XPS or ESCA). However, this technique is often not adequate to determine the molecular structure of polymers. This has prompted many workers to explore the potential of SIMS for this work (11-16). Significant problems encountered with ion beam bombardment in conjunction with electron beam charge neutralization have been drift in the polymer surface potential and thermal damage from the combined effects of the electron and ion beams. These problems do not exist when utilizing FAB in conjunction with photoelectron charge neutralization.

Figures 7a, b, and c show the SIMS spectra of known polymers PTFE, FEP, and PVF₂. Briggs and Wootton (13) report that radiation from electron beam charge neutralization

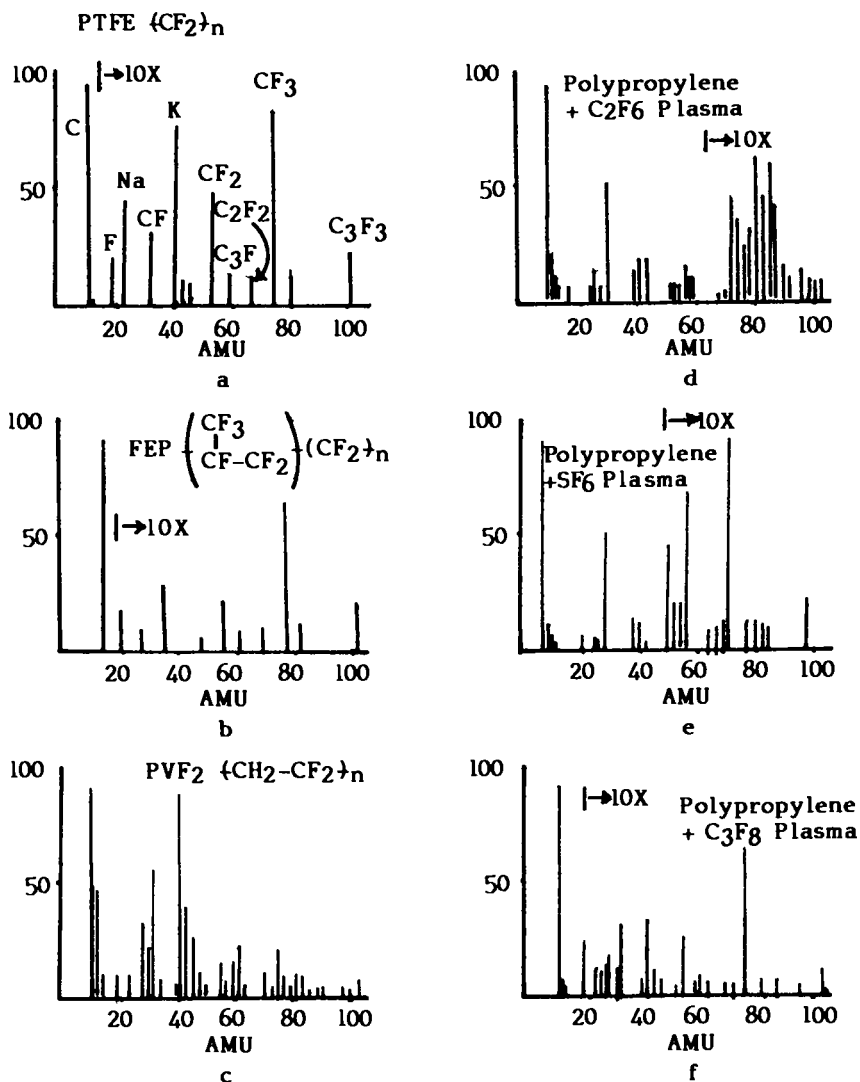


Figure 7. FAB SIMS Spectra of Fluoropolymers and Plasma Treated Polypropylene Surfaces

in itself caused significant emission of molecular ions such as CF_3^+ from surfaces such as PTFE. This was confirmed in this laboratory. No desorbed ions were observed with the mercury photoelectron method of charge neutralization. Figures 7d, e, and f show the SIMS spectra of polypropylene which has been surface modified by plasma treatment in the fluoride gas indicated. The peak intensity values from 12 through 35 AMU were normalized to carbon M/Z 12 intensity and are tabulated in Table II. SIMS spectra of PTFE and FEP do not show the hydrocarbon fragmentation series characteristic of the other surfaces because the hydrogen atoms are fully substituted by fluorine. Mass 13 for these samples shows 2% of the mass 12 peak. Carbon ^{13}C accounts for 1% of this; the remaining 1% is likely due to surface contamination. The first difference between these two samples occurs at M/Z 69 (CF_3^+) where this peak is about twice the intensity for the FEP samples as the PTFE surface. At higher M/Z values, additional differences are observed. The relative intensities of peaks M/Z $^{13}\text{CH}^+$, $^{14}\text{CH}_2^+$, and $^{15}\text{CH}_3^+$ for the plasma treated polypropylene surfaces are an indication of the amount of fluorine substitution. This is confirmed by the XPS or ESCA carbon (1s) spectra of the same samples which are shown in Figures 8a, b, and c. The intensity of the XPS hydrocarbon peaks show general agreement with the intensity of the peaks at M/Z 13, 14, and 15 in the SIMS spectra.

The negative FAB SIMS spectra of the fluoropolymers did not contain any particularly useful information. The major peak observed is at M/Z 19 F^- . Small peaks of one percent intensity or less are observed at M/Z 12 C^- , 16 O^- , 24 C_2^- , 31 CF^- , and 38 F_2^- . Our experience suggests that negative FAB SIMS appears to be the most useful for the determination of the relative amount of oxygen in the polymer structure since positive SIMS has low sensitivity for oxygen and potential interference from hydrocarbons at M/Z 16.

Conclusion

FAB SIMS in conjunction with charge neutralization utilizing mercury discharge lamp induced photoelectrons permits low-damage highly reproducible analysis of electrically insulating surfaces. Stable spectra can be obtained from polymeric materials such as polyethylene for periods of an hour or more. Minor spectrum differences between samples such as the various oxides of cobalt, which may have previously been due to thermal or surface potential effects, can now be more confidently assigned to compositional differences.

Table II. Normalized Peak Intensities for the Spectra shown in Figure 7

AMU	PTFE $\{CF_2\}_n$		FEP CF_3 $\{CF-CF_2\}_n$		PVF ₂ $\{CF_2-CH_2\}_n$	C ₂ F ₆ Plasma on Polypropylene		SF ₆ Plasma on Polypropylene		C ₃ F ₈ Plasma on Polypropylene												
	100	2	100	2		100	28	15	7	3	100	14	7	3	1	100	14	7	3			
12 C	100		100		100		100		100		100		100		100		100		100		100	
13 C ₁₃ CH	2		2		64		28		14		9		9		9		9		9		9	
14 CH ₂					49		15		7		3		3		3		3		3		3	
15 CH ₃					11		7		3		1		1		1		1		1		1	
16 CH ₄ , O																						
17																						
18																						
19 F	1		1		10		4		3		2		2		2		2		2		2	
20																						
21																						
22																						
23 Na		4			11				6		1		1		1		1		1		1	
24 C ₂					4				<1		<1		<1		<1		<1		<1		<1	
25 C ₂ H					8		2		1		1		1		1		1		1		1	
26 C ₂ H ₂					20		6		4		4		4		4		4		4		4	
27 C ₂ H ₃					35		15		7		7		7		7		7		7		7	
28 C ₂ H ₄					14		2		1		1		1		1		1		1		1	
29 C ₂ H ₅					24		8		3		3		3		3		3		3		3	
30 C ₂ H ₆					8		8		7		7		7		7		7		7		7	
31 CF					60		58		46		35		35		35		35		35		35	
32 CHF					5		2		1		1		1		1		1		1		1	
33 CH ₂ F					10		1															
34																						
35																						

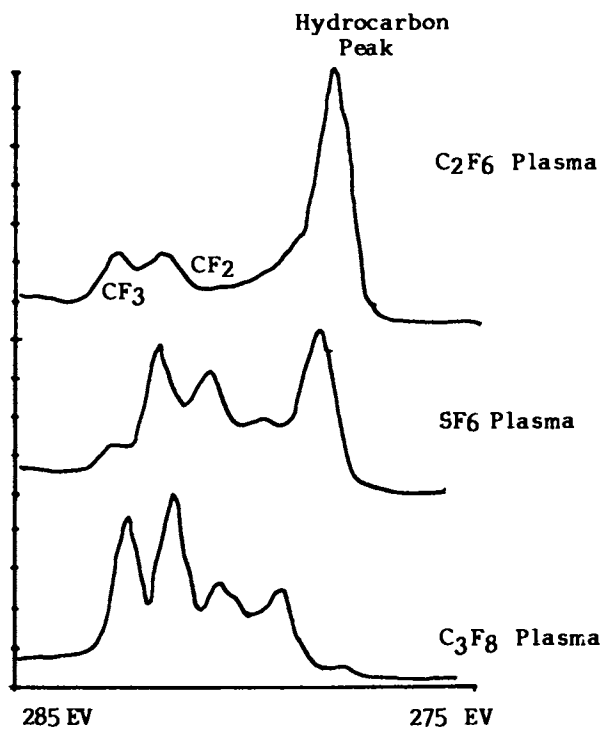


Figure 8. XPS Carbon (1s) Spectra of Plasma Treated Polypropylene

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Secondary Ion Mass Spectrometry: A Multidimensional Technique

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This paper discusses SIMS as a multi-dimensional technique for the analysis of inorganic and organic materials. The paper is divided into two parts: inorganic SIMS and organic (molecular) SIMS. The inorganic SIMS part focuses on methods of quantitative analysis and depth profiling applications. In particular, the parameters that makes SIMS difficult to quantify - secondary ion yield, matrix effects, and instrumental effects - are reviewed as well as the various physical models and empirical methods used to quantify SIMS data. The instrumental and experimental parameters that affect SIMS depth profiling are also reviewed. The organic SIMS part discusses the method of ionization and the various sample preparation and matrix-assisted procedures used for analysis. The matrices include various solid-state and liquid matrices such as ammonium chloride, charcoal, glycerol, and gallium. A neutral beam source was developed to analyze thick, insulating films. Various chemical derivatization procedures have been developed to enhance the sensitivity of molecular SIMS and to selectively detect components in mixtures.

Bombarding a solid surface with low energy (keV) ions or neutrals results in the emission of secondary particles: positive and negative ions, neutrals, electrons, and photons. This phenomenon, known as sputtering, is dependent on several important parameters such as the energy, mass, and angle of the incident beam and the mass, structure, and binding energy of the atoms which form the surface of the target [1]. Mass analysis of the sputtered secondary ions forms the basis of secondary ion mass spectrometry (SIMS) [2].

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As a surface analytical tool, SIMS has several advantages over X-ray photoelectron spectroscopy (XPS) and Auger electron spectroscopy (AES). SIMS is sensitive to all elements and isotopes in the periodic table, whereas XPS and AES cannot detect H and He. SIMS also has a lower detection limit of $\sim 10^{-5}$ atomic percent (at.%) compared to 0.1 at.% and 1.0 at.% for AES and XPS, respectively. However, SIMS has several disadvantages. Its elemental sensitivity varies over five orders of magnitude and differs for a given element in different sample matrices, i.e., SIMS shows a strong matrix effect. This matrix effect makes SIMS measurements difficult to quantify. Recent progress, however, has been made especially in the development of quantitative models for the analysis of semiconductors [3-5].

SIMS methodology has evolved along two distinct lines. The first and original method showed SIMS as an analytical tool for depth profiling and microanalysis. Specialized instruments with microscope or microprobe capabilities were developed for depth profiling, ion imaging and micro-area analysis [2,6]. This SIMS method, commonly referred to as "dynamic SIMS", uses a relatively high primary ion beam flux ($> 1 \times 10^{-6}$ A/cm²) to generate specimen sputtering rates of > 50 Å/min. The high sputtering rates enhance the sensitivity of the method. The dynamic SIMS method has been applied primarily to studies in electronic technology and material science [7-9].

The second SIMS method was pioneered by A. Benninghoven (Univ. of Munster, West Germany) in the late 1960's and is capable of analyzing surface monolayers [10]. To achieve monolayer sensitivity, it is first necessary to reduce the sample sputtering rate by lowering the primary ion beam flux (typically $< 1 \times 10^{-9}$ A/cm²) and second, in order to compensate for the corresponding loss in signal intensity (due to the lower flux), the analysis area is increased by broadening or rastering the primary ion beam. This SIMS method known as "static" [12,13] or low damage [14] SIMS has been applied to the study of gas-surface interactions [7-9,15-17]. (The pioneering work of Macfarlane (Texas A&M University) dealing with Californium-252 plasma desorption mass spectrometry was important in establishing that large organic molecules could be desorbed as intact molecular and molecular-like ions [11]).

As a sub-element of the static SIMS methodology, SIMS has become (most recently) a new ionization source for the analysis of nonvolatile and thermally labile molecules including polymers and large biomolecules such as proteins. Since most of these latter studies deal with the emission of polyatomic or molecular ions, the name "molecular SIMS" has been applied [18-21].

The application of molecular SIMS as a sensitive ionization source for nonvolatile and thermally labile molecules compares favorably with other new ionization methods in mass spectrometry such as field desorption (FD), Californium-252 plasma desorption (PD), fast heavy ion induced desorption (FHIID), laser desorp-

tion (LD) or laser microprobe mass analysis (LAMMA), and fast-atom bombardment (FAB) or liquid SIMS [21-23]. In each of these techniques, the molecules are desorbed and ionized directly from the solid state and appear as molecular and/or molecular-like (protonated, deprotonated, and/or cationized) ions, e.g., M^{\pm} , $[M \pm H]^{\pm}$ and $[M + \text{cation}]^+$.

This paper discusses SIMS as a multi-dimensional technique for the analysis of inorganic and organic materials. The paper is divided into two parts: inorganic and organic (or molecular) SIMS. The inorganic SIMS part focuses on the methods of quantitative analysis and depth profiling applications. In particular, SIMS matrix effects are defined and the physical models and empirical methods used to quantify SIMS results are reviewed.

The emission of molecular ions in organic SIMS is discussed with respect to the method of ionization and the various sample preparation and matrix-assisted procedures used. The matrices include various solid-state and liquid matrices such as ammonium chloride, charcoal, glycerol, and gallium. A neutral beam source is described to analyze thick insulating films. Various chemical derivatization procedures have been developed to enhance the sensitivity of molecular SIMS and to selectively detect components in mixtures.

Inorganic SIMS

The results discussed in this section deal primarily with the methods used to quantify dynamic SIMS results obtained from depth profiling studies of inorganic materials such as semiconductors.

Quantitative Analysis. SIMS has many unique features (compared to other surface analytical techniques) such as hydrogen and isotope detection, a detection limit as low as 10^{-14} g, surface/monolayer sensitivity, compound specificity, and high spatial resolution ($<1000\text{\AA}$). In addition, SIMS is perhaps the most versatile surface analytical technique. It can depth profile semiconductors, image biological tissues, study gas-surface interactions/adsorbate geometry, and ionize nonvolatile and thermally labile molecules. However, it is often said that "SIMS is difficult to quantify". While this statement is true to a large extent, recent progress has been made to develop quantitative methods that convert measured secondary ion intensities to atomic concentrations and to apply these methods to analyze depth profiles and ion images. The quantitative methods used in SIMS have been reviewed recently by Werner [3], Wittmaack [4] and Morrison [5]. Magee and Honig [24], Hofmann [25,26] and Wittmaack [27] have reviewed the application of these methods to depth profile analysis.

An example of a SIMS depth profile is shown in Figure 1 for a ^{11}B implanted Si specimen. The profile is plotted after a fashion being promoted by the ASTM E-42.06 Surface Analysis subcommittee on SIMS. The depth profile is recorded by monitoring the secondary ion intensity (in counts per second) of the $^{11}\text{B}^+$ implanted species and the $^{30}\text{Si}^+$ matrix element as a function of sputtering time (in seconds). The plot of secondary ion intensity versus sputtering time represents the raw experimental data which are converted to the ^{11}B atomic concentration (in atoms/cm³) and depth (in nanometers). The concentration scale is obtained using a standard reference specimen (as will be described below); and the depth scale is obtained by measuring the depth of the sputtered crater by profilometric or interferometric techniques. (Assigning a linear depth scale assumes a linear sputter rate which may not apply. See below for a discussion of nonlinear sputtering effects.)

Let us begin by looking at the parameters that make SIMS measurements difficult to quantify. First, the secondary ion yield (defined as the ratio of the number of secondary ions sputtered from the surface of a solid sample to the number of primary ions incident upon the specimen) varies over four orders of magnitude from element to element. Second, the yield of each ion is affected by the composition of the matrix. This is the well known SIMS "matrix effect". Third, instrumental effects and ion collection/detection efficiencies can vary from instrument to instrument and specimen to specimen.

Secondary ion yields are defined as the total number of secondary ions sputtered from the specimen per incident ion of given mass, energy, charge, and angle of incidence [27]. Positive secondary ion yields are enhanced by oxygen and other electronegative reactive species and negative secondary ion yields are enhanced by cesium and other electropositive reactive species [4]. Depending upon the sample matrix, reactive materials have increased the secondary ion yields of some elements by orders of magnitude [29]. The energy of the primary ions, the mass of the primary ions, and the sputtering yield determine the concentration of the primary ion that is implanted into the sample matrix once equilibrium between the rate of implantation and sputtering is reached [30]. The nature and concentration of the implanted species also affects directly the secondary ion yields.

Anderson and Hinthorne [31] have determined that for positive secondary ions an element's secondary ion yield is inversely proportional to the first ionization potential of an element. A similar relationship has been established between negative secondary ion yields and electron affinities [4,31,32].

The SIMS "matrix effect" is defined as any change in the secondary ion yields which are caused by changes in the chemical composition or structure of a particular specimen [28]. An example of the SIMS matrix effect is illustrated in Figure 2 for

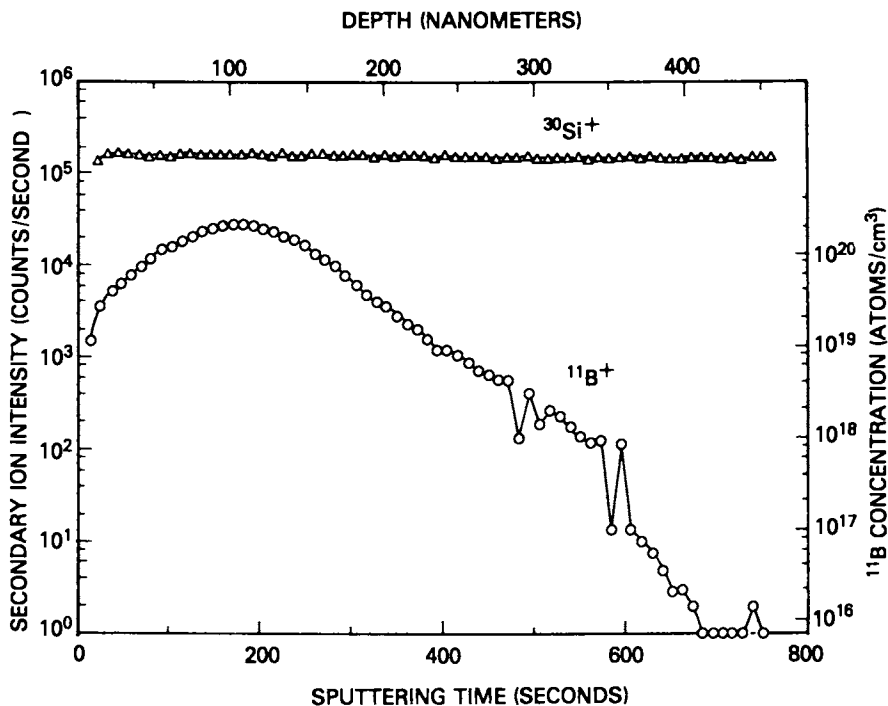


Figure 1. SIMS depth profile of a $^{11}\text{B}^+$ ions implanted Si specimen.

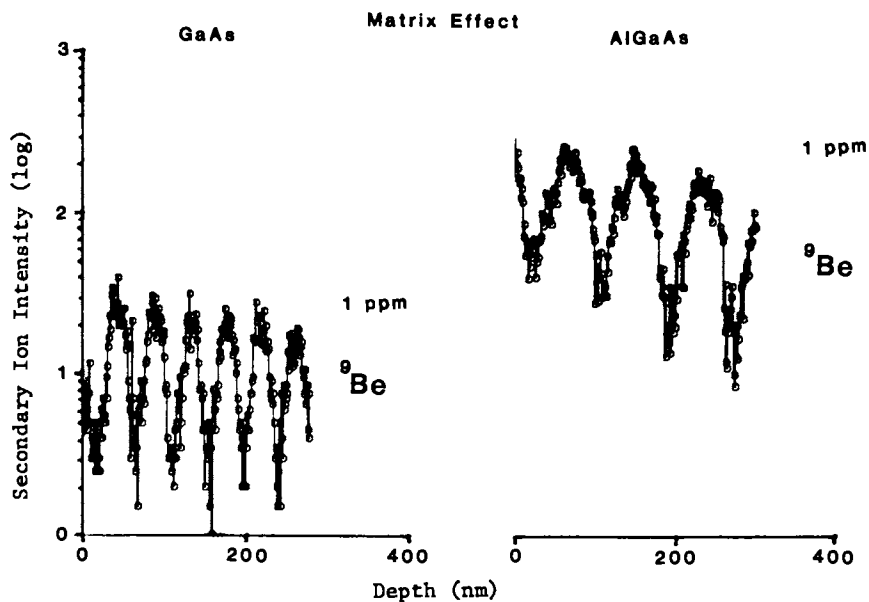


Figure 2. SIMS depth profile of $^9\text{Be}^+$ ions in GaAs and AlGaAs matrices.

Be layers grown by molecular beam epitaxy (MBE) in GaAs and AlGaAs matrices. Even though the concentration of Be in both matrices is approximately the same, i.e., 1 ppm or $\sim 2 \times 10^{16}$ atoms/cm³, the secondary ion intensity of ⁹Be⁺ ions differs by about a factor of ten. The Be⁺ ion yield from AlGaAs is higher than from GaAs. The variation of secondary ion yields by an order of magnitude occurs for most elements implanted into different semiconductor matrices [33,34].

Other examples of SIMS matrix effects follow. When argon was used as the primary ion, Slodzian [35] determined that the ion yield of Ta⁺ from Ta metal was three orders of magnitude lower than the ion yield from Ta oxide. Ganjei, Leta, and Morrison [36] have determined that secondary ion yields do not change uniformly for different elements in steels and other metallurgical materials when the residual oxygen pressure of the sample chamber is increased (a comparison of secondary ion yields from amorphous and polycrystalline iron based alloys [37] concluded that a small but significant matrix effect existed for the matrix elements iron and boron in a series of specimens.) On the other hand, in glass matrices, Ganjei and Morrison [37] found that oxygen did not affect the secondary ion yields probably because the glass matrices were already saturated with oxygen.

The sputtering yield of a material is also matrix dependent. The sputtering yield is defined as the ratio of the number of ions and atoms sputtered from the surface of a specimen to the number of primary ions incident upon the specimen [28]. Single crystal materials with the same crystal orientation under the same experimental conditions will have uniform sputtering rates. The sputtering rate can be determined from the area that was sputtered and the number of primary ions that impinged upon that area. However, changes in the crystal orientation of a single crystal have changed sputtering yields by up to 50% [33,34]. Also, different chemical phases usually have different sputtering yields. Sputtering yield effects are usually considered to be matrix effects.

In particular, Katz et al. [39] found a linear correlation between sample sputtering yield and average sample mass. With this relationship the authors could predict ion yields and detection limits of related compounds. In another study involving pure elemental matrices, an inverse relationship was determined between a matrix element's secondary ion yield and the sputtering rate of that matrix when either cesium or oxygen was used as the primary ion [40-43]. A similar relationship was found for secondary ion yields of trace elements in single element matrices [32]. These authors concluded that only the ionization potential or electron affinity of the sputtered atom and the near-surface concentration of oxygen or cesium controlled secondary ion yields. Furthermore, they concluded, that at least for metal silicides, group IV elements, and GaAs, the matrix effect is merely an artifact caused by different

sputtering yields. However, Wittmaack [44] has noted that the precision of the results did not in his opinion justify their conclusions, and that matrix effects are actually present within the experimental error of the data which had been presented logarithmically. Also, important physical processes such as differential sputtering were not considered, and would preclude the application of this model to materials with complex matrices.

Galuska and Morrison [45] showed that the secondary ion yields and sputtering yields of $\text{Al}_x\text{Ga}_{1-x}\text{As}$ matrices are linearly dependent on the sample composition. Relative ion yield, and relative sputtering yield calibration lines are used to determine the concentration of B implanted into a multilayer-multimatrix specimen. In other work [46], they applied a point-by-point matrix effect calibration procedure to a variety of $\text{Al}_x\text{Ga}_{1-x}\text{As}$ multilayer-multimatrix specimens grown by MBE. The procedure used the linear dependence of secondary ion yields and sputtering yields on matrix composition to quantify depth profiles through matrix gradients and interfaces. In the actual procedure, a computer program is used to correct depth profiles for matrix effects. For example, for $\text{Al}_x\text{Ga}_{1-x}\text{As}$ matrices, the matrix composition and depth at each point of a depth profile is determined by an interactive process involving calibration lines for both relative sputtering yield and the relative ion yield of $^{75}\text{As}^+$. Dopant profiles are then corrected for matrix changes by use of the appropriate dopant calibration lines.

Rudat and Morrison [47] have determined that instrumental transmission factors change as a function of the residual oxygen pressure in the sample chamber for the analyses of single elemental matrices.

Useful Ion Yields. Quantitation of SIMS results requires one to determine the relationship between the measured secondary ion intensities, I , and the original elemental concentration of the solid. For a particular element M the measured secondary ion intensity has been defined by Morrison and Slodzian [6] as

$$I = \tau^{\pm} C_m S J_p A \quad (1)$$

where τ is the practical or useful ion yield, C_m is the concentration of the element M corrected for its isotopic abundance, S is the total sputtering yield, J_p is the primary beam current density, and A is the analysis area of the target surface. The useful ion yield is defined as the ratio of the number of M^+ ions detected to the total number of atoms sputtered from the solid surface. The difficulty of solving Equation 1 for C_m is that for complex matrices the useful ion yield and the total sputtering yield are not known.

An element's useful ion yield is inversely proportional to the element's first ionization potential and affected by various instrumental factors and sampling conditions, the chemical state

of the element, and the chemical and physical properties of its location in the solid. If the sputtering rate can be determined, the chemical composition and density of the matrix are known, and there is no preferential sputtering, then the useful ion yield can be determined experimentally. If the matrix of a standard and a sample are identical, then the measured useful ion yield from the standard can be used in Equation 1 to solve for C_m in the specimen. Useful ion yields have been determined for elements implanted in single crystal semiconductors by Leta and Morrison [33] and can be used as standards for similar semiconductor materials. Because instrumental and sampling parameters affect the useful ion yield, it is necessary to determine useful ion yield values for the standards at the same time that the specimen is being analyzed. Depending upon the matrix in which they are implanted, some of the element's useful ion yields were found to vary by up to an order of magnitude.

Physical Models. Two basic approaches are used to quantify secondary ion intensities: physical models and empirical methods. The physical models consist of several theoretical or semi-empirical treatments developed to simulate secondary ion emission [3,48-50]. Although several models have been developed (see Werner [3] for a recent review) and continue to be applied, the use of calibration standards (empirical methods) consistently give better results, e.g., accuracies of a factor of 2-3 for physical models compared to 10-20% for empirical methods.

The physical models attempt to account for the influence of such parameters as ionization potential, work function, and binding energy on the secondary ion yield in order to describe the ion emission process. While there are perhaps over 20 different models, some of the well-known models include the kinetic model [51] which describes ions formed by an Auger de-excitation process of excited neutral particles emitted by collision cascade; the auto-ionization model [52-54], valid for rare-gas ion bombardment, which postulates bombardment induced inner shell excitation into an auto-ionizing state and relaxation via an Auger process; surface effects models [55-59] where a particle while being ejected is assumed to change its electronic structure at or near the surface of the specimen via electron transitions; and various thermodynamics models including the well-known local thermal equilibrium (LTE) model [31], simplified 2-parameter [60-61] and 1-parameter [62-65] LTE models, and a local thermal nonequilibrium model [65-68].

The LTE model has been a point of controversy for several years [50] because the values used in the Saha-Egget equation to approximate the temperature and electron density of the assumed plasma are unrealistically high. The model nevertheless continues to be used in SIMS and for some cases the results can be quite good. It is recommended, however, that the model be tested against suitable calibration standards prior to analyzing unknowns [69-71].

Newbury [72] found that a major source of error in the LTE model originates from instrumental discrimination. Sources of such discrimination include the energy bandpass of the secondary ion spectrometer and conversion efficiencies of the ion detector.

Empirical Methods. The empirical methods use calibration standards to derive sensitivity factors that can be used to determine the unknown concentration of given elements in similar matrices [3]. The sensitivity factors are derived from calibration curves that plot measured secondary ion intensities versus the known concentration of standards. Three types of sensitivity factors have been used: the absolute sensitivity factor, the relative sensitivity factor, and the indexed relative elemental sensitivity factor.

The absolute sensitivity factor (ASF) is defined as

$$\text{ASF}_x = \frac{I_x}{C_x f_x} \quad (2)$$

where I_x is the measured secondary ion intensity of one isotope of element X, C_x is the concentration of element X, and f_x is the isotopic abundances of the elemental isotope being measured.

Quantitative information is obtained by determining the ASF_x from the calibration curve generated using external standards. Ideally, the plot of I_x versus C_x gives a straight line with slope equal to ASF_x . For best results, the matrix of the specimen must be the same as the external standard. In addition, instrumental factors (such as angle of incidence, collection/detection efficiency, etc) and matrix-dependent factors (sputtering yields, ion yield, etc.) must also be the same. There are no corrections for experimental variations or preferential sputtering. For identical inorganic specimens and standards quantitation with high accuracy has been achieved by the ASF method.

The relative sensitivity factor (RSF) is defined as

$$\text{RSF}_{x/\text{ref}} = \frac{I_x/C_x f_x}{I_{\text{ref}}/C_{\text{ref}} f_{\text{ref}}} \quad (3)$$

where I is the measured secondary ion intensity, C is the elemental concentration, f is the isotopic abundance, and the subscripts x and ref denote the analyte and reference elements, respectively.

Quantitative information is obtained by determining the RSF from a calibration curve generated by plotting I_x/I_{ref} versus C_x/C_{ref} . An internal reference element ("ref") is used to eliminate long-term instrument instabilities such as drift in the instrument or fluctuations in the primary ion current. The internal reference element is usually a matrix element. For example, a calibration curve used in our laboratory for the quantitation of Be in GaAs is shown in Figure 3. The secondary ion intensity of ${}^9\text{Be}^+$ (normalized to the internal reference element, the matrix element ${}^{75}\text{As}^+$) is plotted against the concentration of Be in the standards. Since the Be concentration is several orders of magnitude lower than the matrix elements, the concentration of the ${}^{75}\text{As}$ matrix element, i.e., As, is assumed to be constant.

The reference element included in the RSF method compensates for some types of experimental fluctuations. The RSF method has been applied to the elemental determinations in groups of similar inorganic matrices including glasses [37,73-75], metals [37,75], and minerals [76]. If the specimen and reference matrices are similar, the RSF method has been shown to give a precision of $\pm 15\%$ [73].

The indexed relative elemental sensitivity factor or matrix ion species ratio (MISR) [2,36,77] indexes changes in the relative sensitivity factors to changes in the surface composition, particularly, if the surface is exposed to or bombarded with oxygen. For example, when oxygen is leaked into the specimen chamber, a calibration curve can be generated that plots the RSF's as a function of the MO^+/M^+ ion ratio. The MO^+/M^+ ion ratio is chosen as an internal indicator because it was found to be very sensitive to the oxygen surface coverage which, in turn, affects the secondary ion yields. With the indexed RSF method a substantial improvement in precision to $\pm 5-10\%$ has been achieved over the simple RSF method [2], particularly, for the quantitation of metals.

One problem in quantitative SIMS is caused by variations of the instruments. To evaluate these instrumental factors, Newbury [70] conducted comparative SIMS studies of selected glasses and steels with laboratories in the U.S., Japan, and Europe. He had each laboratory calculate relative sensitivity factors for several elements under a variety of experimental conditions. These results were astonishing and showed that a given relative sensitivity factor varied from 5 to 60. He also compared the measured concentrations with predicted values from physical models.

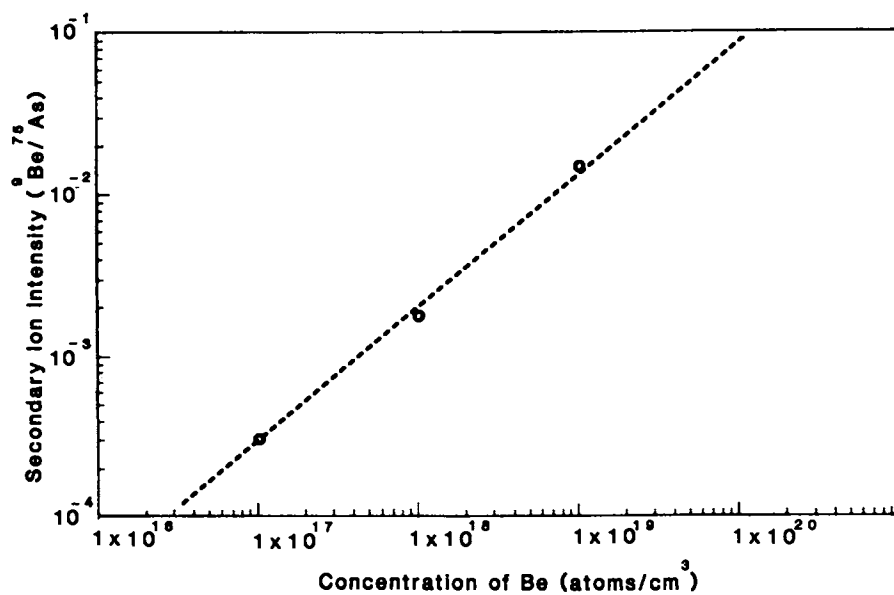


Figure 3. SIMS calibration curve for the quantitation of Be in GaAs.

Calibration Standards. The empirical methods use calibration standards which are typically from glasses or iron alloys that are chemically doped with elements of known concentrations. The National Bureau of Standards (NBS) supplies several characterized standards of this type.

Metallic glasses are also being used as standards. Rudenauer and coworkers [78, 79] use metallic glasses as standards for several reasons: 1) the metallic glasses are single phase systems and are homogeneous at the micron scale; 2) metallic glasses can be prepared in a broader concentration range than alloying components, and even insoluble elements can form an amorphous phase under suitable conditions; 3) the ion yields of elements in isotopic amorphous alloys are not-dependent on the orientation of the bombardment surface; and 4) amorphous alloys have metallic character.

One problem, however, associated with the use of bulk standards in SIMS is homogeneity. This is particularly acute for the iron alloys. A recent SIMS study concluded that some of the NBS steel standards are unsuitable as standards in SIMS because all of the elements are not homogeneous within the sampling area of 100\AA [36, 69]. Therefore, researchers must be careful in both their choice of standard and which elements in each standard are suitable calibrants.

One way to overcome the sample homogeneity problem has been to develop standards by ion implantation [80-83]. Here, the concentration and distribution of the dopants can be controlled more accurately, thereby forming standards with better homogeneity. However, the results with semiconductors, have been much more reliable than with ion-implanted metal standards [82, 83].

Leta and Morrison [82, 83] have described a new empirical method for quantitative SIMS analysis. They use the method of solid-state addition in which they implant their specimens with a known concentration of the element of interest. Since the depth profile of the implanted species has a characteristic Gaussian shape, it is easily distinguished from the element originally present in the specimen. Therefore, the known concentration of the implanted element is used as an internal standard to determine the concentration of the unknown.

Depth Profiling. As the sputtering process in SIMS removes successive atomic layers from the solid, the in-depth composition and distribution of elements can be determined by recording the secondary ion intensity for each element as a function of sputtering time, producing a sputter depth profile. The secondary ion intensities are usually converted to their respective atomic concentrations by the appropriate quantitative methods discussed above and the time axis is converted to a depth (distance) scale (see Figure 1). Although sputter depth profiling has found widespread application in the semiconductor

industry, there are various effects associated with ion-solid interactions that are not yet well enough understood to convert the measured depth profile to the true concentration profile of the specimen.

Many of these effects in SIMS depth profiling have been reviewed recently by Wittmaack [27], Hofmann [25, 26] and Magee and Honig [24]. Wittmaack [27] has written an excellent review detailing the recent progress and basic physical problems encountered in depth profiling by SIMS. He shows that SIMS has reached a level of perfection which is unparalleled by other analytical techniques, particularly the in-depth analysis of low concentration implants. There are analysis problems, however, caused by the interaction of primary ions with the residual gas, the adsorption and incorporation of residual gases, sputtering yield variations due to the accumulation of primary atoms in the specimen, mass interference between polyatomic ions and the atomic species under study, and beam-induced relocation of dopant atoms, i.e., atomic mixing effects. Hofmann [26] also summarizes the distorting effects in sputter depth profiling as due to instrumental factors (e.g., adsorption of residual gases, redeposition of sputtered species, crater edge effects, impurities in the ion beam, neutrals from the ion source, nonuniform ion beam intensity, mean information depth), specimen characteristics (e.g., original surface roughness, crystalline and defect structure, multiphases or compounds, insulators), and radiation induced effects (e.g., primary ion implantation, atomic mixing, enhanced diffusion and segregation, sputtering induced roughness, preferential sputtering, and specimen decomposition).

Hofmann (25, 26) discusses ways to minimize these effects as well as their influence on depth resolution. For example, the effects of surface contamination are reduced by using a high purity ion beam and UHV conditions. Sputtering with reactive ions reduces topographical change and favors quantitative analysis. Using two ion guns at different angles and rotating the specimen will suppress incident angle dependent texturing and core formation. Recoil implantation and atomic mixing effects are reduced by using heavy primary ions with low energy (<1 keV) and at oblique incidence. Ion beam rastering provides uniform sputtering and raster gating avoids crater edge effects. Optimal results are also expected for solids having a) flat and smooth surfaces, b) amorphous structures with no second phases, and c) components with similar sputtering yields. Specimens with high electrical and thermal conductivity are also preferred.

In another review, Magee and Honig [24] discuss three important aspects of depth profiling by SIMS: depth resolution, dynamic range and sensitivity. First, the depth resolution is a measure of the profile quality. They point out that the depth resolution is limited by atomic mixing effects and the flatness of the sputtered crater within the analyzed area. Second, the dynamic range of depth profiles is limited by crater edge

effects, neutral beam effects, spectral interferences, residual gas contamination, recontamination from previously sputtered materials, and noise from the detection of nonfilterable particles. Third, in the absence of a measurable background, the ultimate sensitivity of a depth profile analysis is dependent on ion yield and analyzed area and can be increased only at the expense of depth and spatial resolution.

Organic SIMS

SIMS has become a diverse tool in the study of many different substances other than metals and semiconductors. This part of the paper discusses the secondary ion emission of molecular and polyatomic ions from the surfaces of organic compounds including polymers and biomolecules.

Ionization Methods/Processes. The recent development of several new ionization methods in mass spectrometry has significantly improved the capability for the analysis of nonvolatile and thermally labile molecules [18-23]. Several of these methods (e.g., field desorption (FD), Californium-252 plasma desorption (PD), fast heavy ion induced desorption (FHIID), laser-desorption (LD), SIMS, and fast atom bombardment (FAB) or liquid SIMS) desorb and ionize molecules directly from the solid state, thereby reducing the chance of thermal degradation. Although these methods employ fundamentally different excitation sources, similarities in their mass spectra, such as, the appearance of protonated, deprotonated, and/or cationized molecular ions, suggest a related ionization process.

The ionization process in SIMS is undoubtedly dependent on such physical properties as the ionization potential or the electron affinity of a given species. Researchers in molecular SIMS have defined phenomenologically three distinct ionization processes based on the type of ions created and their relative ease of ionization [18].

The first process involves electron ionization to form radical M^+ molecular ions. This process has been observed primarily for nonpolar molecules. The proposed mechanisms are charge-exchange transitions between sputtered ions and the neutral organic molecules or electron attachment of low-energy secondary electrons to neutral molecules. The fragmentation reactions of the M^+ ions usually follow the dissociation pathways for odd-electron gas-phase ions.

The second process involves the formation of protonated or cationized molecular ions, i.e., $[M+H]^+$ or $[M+C]^+$, where the cationizing species C is usually a metal ion from the substrate, matrix, or an impurity. The basic fragmentation process

involves the loss of neutral molecules from the even-electron ions due to unimolecular dissociation reactions which are common in other forms of mass spectrometry, e.g., chemical ionization mass spectrometry.

The third process of ionization in molecular SIMS involves the direct emission of intact (or performed) charged species from the solid state as $[M\text{-anion}]^+$ or $[M\text{-cation}]^-$ ions. SIMS studies of organic salts yield intense cationic and anionic species with little fragmentation [85]. The secondary ion intensity for the organic salts is generally two orders of magnitude higher than that observed in cationization. In fact, the relative ionization efficiency (number of secondary ions desorbed/number of molecules desorbed) for these processes in molecular SIMS is direct emission > cationization > electron ionization. The higher efficiency of the direct emission process lowers the detection limits for organic salts in SIMS such that picogram quantities can be detected [86].

Sample Preparation. The methods of sample preparation affect the chemical and physical properties of the sample molecules and hence can profoundly influence the secondary ion formation/emission process. In earlier molecular SIMS studies the samples were prepared by placing a dilute solution of the compound onto an acid-etched Ag foil [87, 88]. The acid etched surface provides a substrate onto which thin layers of the compound can be deposited from solutions with extended concentration ranges. If on the other hand, the substrate was not etched and the concentration of the solution was too high, the adsorbed molecular film would grow too thick and consequently quench the secondary ion emission.

Derivatizing the neutral sample molecules to form ionic species enhances their secondary ion yield. Derivatization of the neutral sample molecules can often be accomplished by simply adding acid or base to the sample solution, or through the chemical modification of specific functional groups of the molecules, e.g., quaternization reactions [20, 89].

Several other sample preparation methods were developed to simplify the solution-deposition procedures. For example, Cooks and coworkers studied adduct ion formation (cationization) of several organic compounds when the organic was burnished (rubbed) onto a metal foil, mixed with a metal salt and then burnished onto a metal foil, or just mixed with metal powders or salts and pressed into pellets. Not only did the SIMS spectra show dramatic differences in the efficiency of adduct ion formation for different metals, but the sample preparation methods had an equally dramatic effect on the SIMS spectra [18].

Matrix assisted SIMS. Molecular ion emission from a number of solid-state and liquid matrices has been investigated recently. There are two types of solid-state matrices used in molecular SIMS namely, low temperature matrices (such as the rare-gas

solids [90] and frozen molecular solids [91-95]) and room temperature matrices (such as ammonium chloride, NH_4Cl [96-98] and carbon [99, 100]). One important property of these matrices is their ability to matrix isolate and dilute the sample molecules. In addition, because NH_4Cl is not chemically inert, it can protonate molecules more basic than ammonia [96] enhancing their ion yield [97, 98]. The carbon matrix, on the other hand, has the unique property of being able to strongly adsorb many organic molecules, even volatile and nonpolar compounds [99, 100].

The recent use of liquid matrices in SIMS has led to several significant accomplishments, particularly for the analysis of biomolecules by FAB mass spectrometry [101]. In the FAB/liquid SIMS technique, the analyte is dissolved in a liquid matrix, such as glycerol, at some optimum concentration in order to provide a surface which, during particle bombardment, is constantly replenished with sample molecules that diffuse from the bulk to the surface. The mobility of the sample molecules in the liquid matrix is an important property of this type of matrix.

We have recently investigated another type of mobile matrix - a liquid metal [100, 102]. Here, we discovered that ion bombardment of the liquid metal surface, upon which sample particles were deposited, resulted in movement of the sample species towards the primary ion beam where they were desorbed and finally detected by the mass analyzer.

Carbon. Since activated carbons or charcoals are used as adsorbents for airborne or aqueous pollutants, one objective of a recent investigation was to develop a new analytical method for the direct and rapid identification of organic compounds adsorbed on carbon. One important class of organic compounds - the polycyclic aromatic compounds (PACs) were previously difficult to analyze by SIMS because of their low ion yield and low adsorption energies on metal surfaces. By adsorption on carbon volatile organic compounds such as the substituted benzenes (toluene, xylene, and mesitylene) are readily detected without cryogenically cooling the matrix [99]. In fact, the molecular ion signal of toluene lasted for $1/2$ to ~ 1 hour when the carbon was saturated with toluene. Since toluene was detected, but not benzene, the minimum adsorption energy necessary to permit detection is taken to be the heat of adsorption for toluene or ~ 11 kcal/mol.

When the larger nonvolatile PACs are adsorbed on carbon, molecular and cationized ions are also detected readily [99]. We believe that the high surface area and porosity of the carbon provides a three-dimensional matrix over which the sample molecules are dispersed and from which ions can be emitted for extended periods of time. For example, 2 μg of a PAC on carbon

emitted cationized ions for over one hour. A detection limit of ~ 1 ng of phenanthrene on carbon was measured under dynamic sputtering conditions (i.e., $> 1 \times 10^{-7}$ A/cm²).

Figures 4 and 5 show the molecular SIMS spectra of phenanthrene and 9-aminophenanthrene taken from four different matrices: Ag foil, NH₄Cl, carbon, and a liquid metal [103]. We found that the molecular ion yields and ionization efficiencies for phenanthrene (at m/z 178) were similar from the Ag, NH₄Cl and carbon matrices, but that the signal-to-background ratio was much better from the carbon matrix. (The mass peak at m/z 191 is attributed to a contaminant in either the vacuum chamber or sample. Since many different polycyclic aromatic hydrocarbon compounds had been studied over many months, the vacuum chamber and sample carousel had to be cleaned periodically to reduce a contamination problem.) For the 9-aminophenanthrene, on the other hand, its secondary ion yield and ionization efficiency were enhanced by the NH₄Cl matrix as evident by the higher counting rate in Figure 5. This observation demonstrates how the chemical properties of NH₄Cl can influence the secondary ion emission of molecules containing certain functional groups. Further comparison of the matrices showed that the Ag matrix was the easiest to prepare but required a static primary beam to ensure low background and good signal-to-noise. The NH₄Cl matrix enhanced the ion emission for most substituted compounds and worked best (i.e., high signal-to-noise) with a static ion beam. The unsubstituted PACs were most easily analyzed from carbon where use of a dynamic primary beam was possible without increasing the background ion intensity.

Liquid Metal Substrate. Initial experiments using a CAMECA ion microscope (5.5 keV Ar⁺ or O₂⁺ ion beam at $> 1 \times 10^{-6}$ A/cm²) demonstrated that the liquid metal (a gallium/indium alloy) provided a suitable substrate from which long-lived M⁺ ion emission of organic molecules occurred while using a dynamic primary ion beam [100, 102]. The experimental set-up for the liquid metal substrate is shown schematically in Figure 6. We found that ion bombardment of the liquid metal surface, upon which sample particles were deposited, resulted in movement of the sample species towards the primary ion beam where they are desorbed and finally detected by the mass analyzer. This liquid metal substrate offers several advantages over conventional liquid or solid matrices (see Table I). For example, the gallium/indium alloy has a smooth surface onto which solids can be dispersed. The liquid metal is also conducting and has a low vapor pressure.

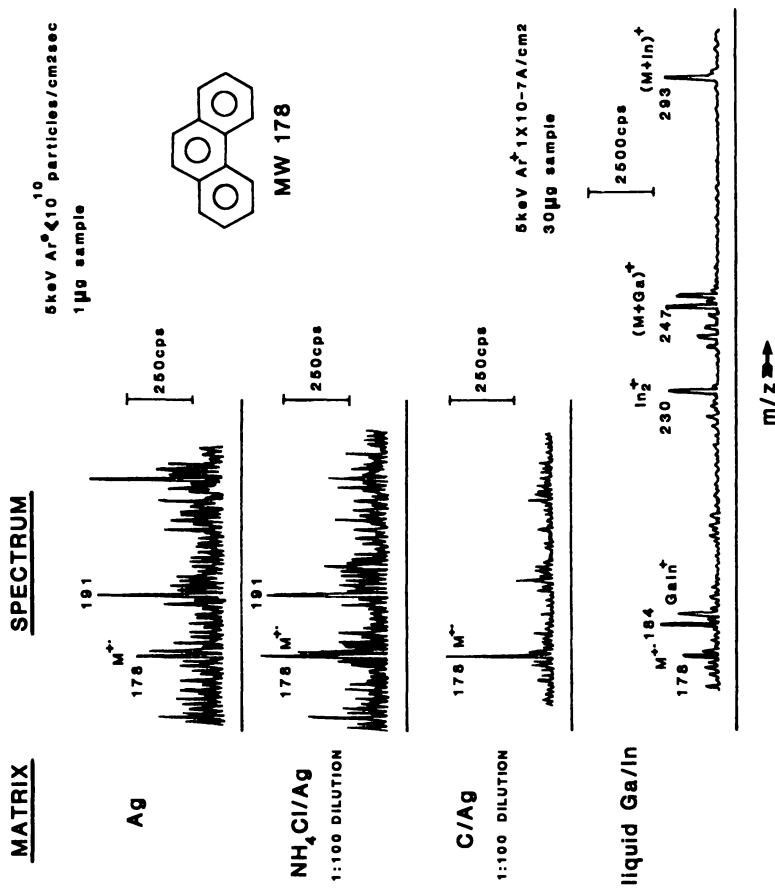


Figure 4. SIMS spectra of phenanthrene taken from silver foil, ammonium chloride, carbon, and liquid gallium/indium alloy. Reproduced with permission from Ref. 103. Copyright 1983, Elsevier Science Publishing Co.

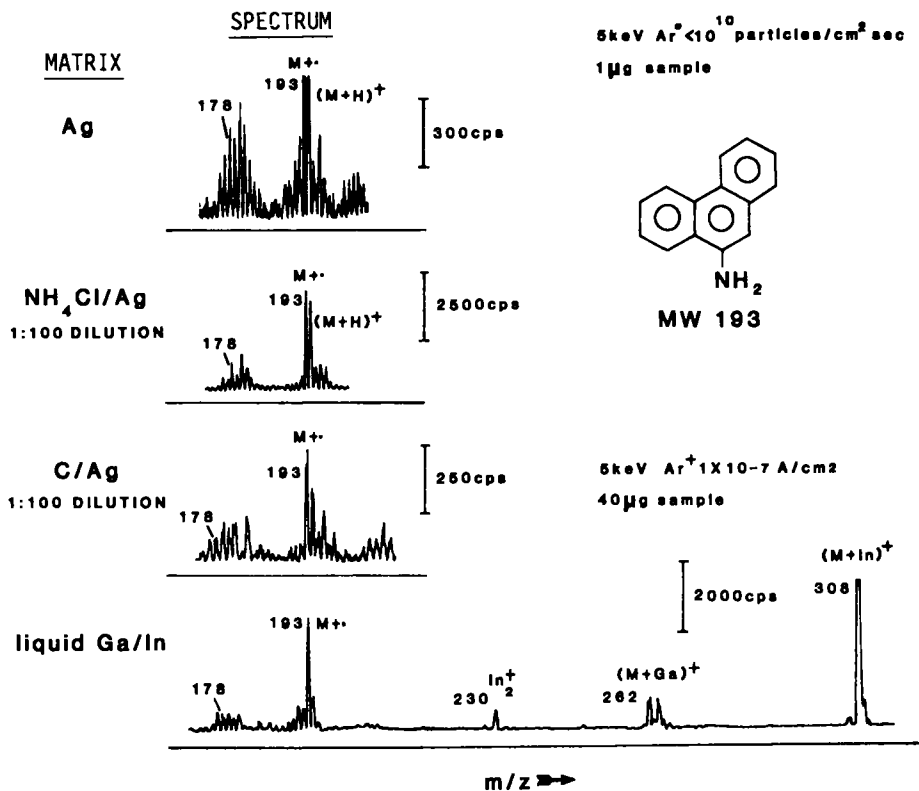


Figure 5. SIMS spectra of 9-aminophenanthrene taken from silver foil, ammonium chloride, carbon, and gallium/indium alloy. Reproduced with permission from Ref. 103. Copyright 1983, Elsevier Science Publishing Co.

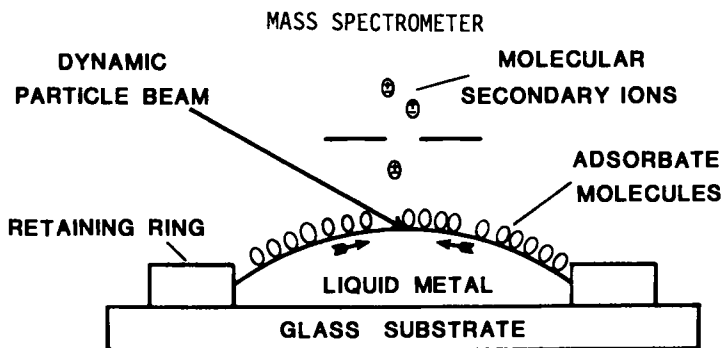


Figure 6. Schematic diagram of the experimental set-up for dynamic SIMS analysis using a liquid metal substrate. Reproduced with permission from Ref. 103. Copyright 1983, Elsevier Science Pub. Co.

TABLE I. Comparisons of the Liquid Metal and Glycerol Substrates for Molecular SIMS

Property	Matrix	
	Liquid Metal ^a	Organic ^b
Sample Introduction	Surface	Bulk Solution
Interference Peaks	Few	Many
Physiochemical Nature of Surface/Liquid	Smooth/Inert	Polar/Selective Solvent
Vapor Pressure	10 ⁻¹¹ torr @ 435 °C	3 x 10 ⁻⁴ torr @ 30 °C
Required Sample Size	1-50 g	10-500 ng
Conductivity	High	Low (must add salt if charging)

^a Ga/In alloy

^b Glycerol

SIMS spectra of phenanthrene and 9-aminophenanthrene analyzed from the liquid metal surface are shown in Figures 4 and 5. The liquid metal substrate requires a dynamic ion beam and sample concentration of 10-40 g for optimum performance in order to sustain the long-lived molecular ion emission. Cationization of the organic molecules by Ga⁺ and In⁺, i.e., [M + Ga]⁺ and [M + In]⁺, occurs with high efficiency.

Polymers. Molecular SIMS is an especially attractive surface analytical technique for the characterization of polymer surfaces because of its high surface sensitivity, molecular specificity over an extended mass range, and versatility in ionization. However, only a few polymer SIMS studies have been reported [104-113] due to the serious sample charging problems that occur with thick insulating films.

A number of experimental methods have been used to reduce the charging of insulator surfaces [114, 115] especially in AES or SIMS experiments where charged primary beams are employed. These methods include (a) electrical compensation, (b) flooding with low-energy electrons or ions, (c) evaporating conducting films or grids onto the surface, (d) increasing the partial pressures of oxygen in order to increase the surface conductivity, (e) emitting secondary electrons from a metal foil placed near the insulator surface, (f) using negative primary ions, (g) using neutral primary particles, (h) using cesium primary ions

or cesium surface overlayers, and (i) heating the specimen. Although a number of these methods have been highly successful in specific cases, the majority of them are experimentally cumbersome and irreproducible.

To overcome this problem, we have modified a commercial ion gun to generate a diffuse fast-atom beam [116, 117]. The ion beam neutralizer shown in Figure 7 consists of a multi-hole metal plate through which the primary ions pass. The ions are neutralized by the ion/surface interactions that occur as the beam passes through the metal apertures and by charge-exchange reactions that occur within the gun assembly. A repeller grid is used to remove the residual ions from the neutralized beam.

The SIMS spectrum of a 0.5 mm thick film of polystyrene cast on silver is shown in Figure 8. The characteristic ions, phenyl-type (m/z 77, 78, 79), benzyl (m/z 91), and protonated styrene (m/z 105) along with higher m/z ions resembling those from pyrolysis studies, are observed.

Derivatization SIMS. The sensitivity of SIMS for quaternary ammonium salts extends to the nanogram or subnanogram range [86]. This enhanced sensitivity forms the basis of a new analytical method to detect organic compounds in mixtures. Specifically, a target compound in a mixture is selectively derivatized to form a quaternary ammonium salt and the derivative is analyzed using SIMS. The compound is derivatized directly in the mixture without sample extraction or clean-up prior to analysis. In addition, because only the derivatized species are detected with high sensitivity, the mass spectra are much simpler and compounds in mixtures can be analyzed using much less complex instrumentation. To date, we have applied these methods to analyze drug compounds from urine [18], to detect aldehydes and ketones [119] in air or adsorbed on activated charcoals [120], to sequence peptides [121] and other biomolecules [122].

Detection of Drugs. SIMS has been applied previously to the detection of several drugs in urine [123]. We have demonstrated picogram sensitivity for drugs in urine by first performing a simple derivatization with methyl iodide, according to Equation 4 to form a quaternary ammonium salt of the drug prior to analyzing the urine with SIMS [118].

BASIC DRUG^{*} DERIVATIZATION SCHEME

Basic Drug (in water or urine)/ MeOH + CH₃I



(4)

*Drugs containing amines

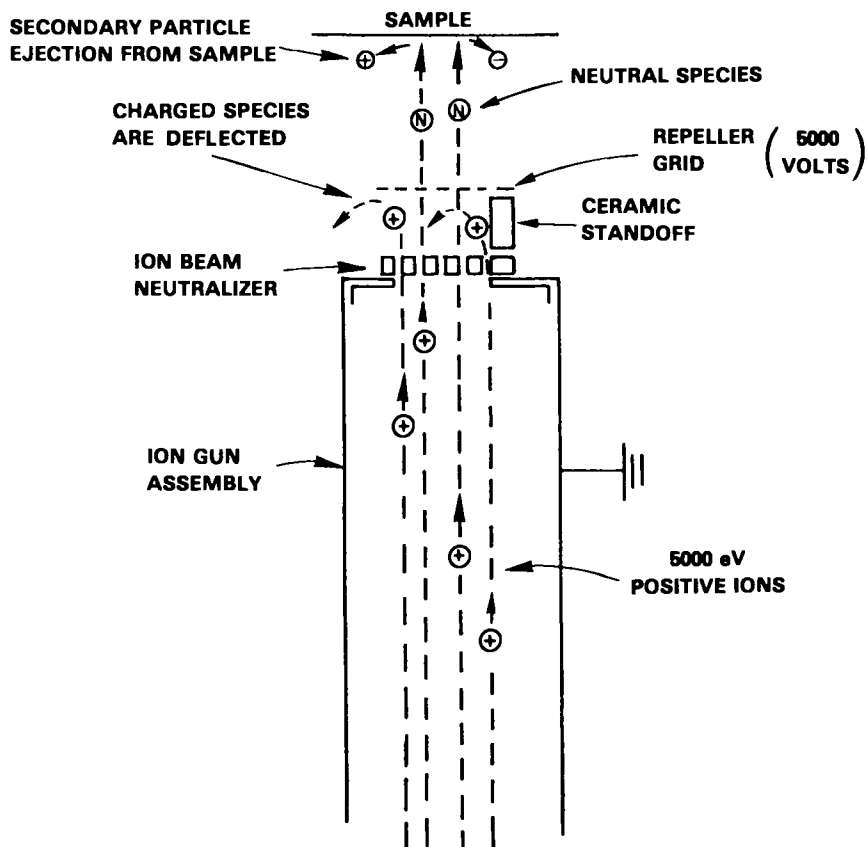


Figure 7. Schematic diagram of commercial ion gun modified with an ion beam neutralizer. Reproduced with permission from Ref. 116. Copyright 1983, Elsevier Science Publishing Co.

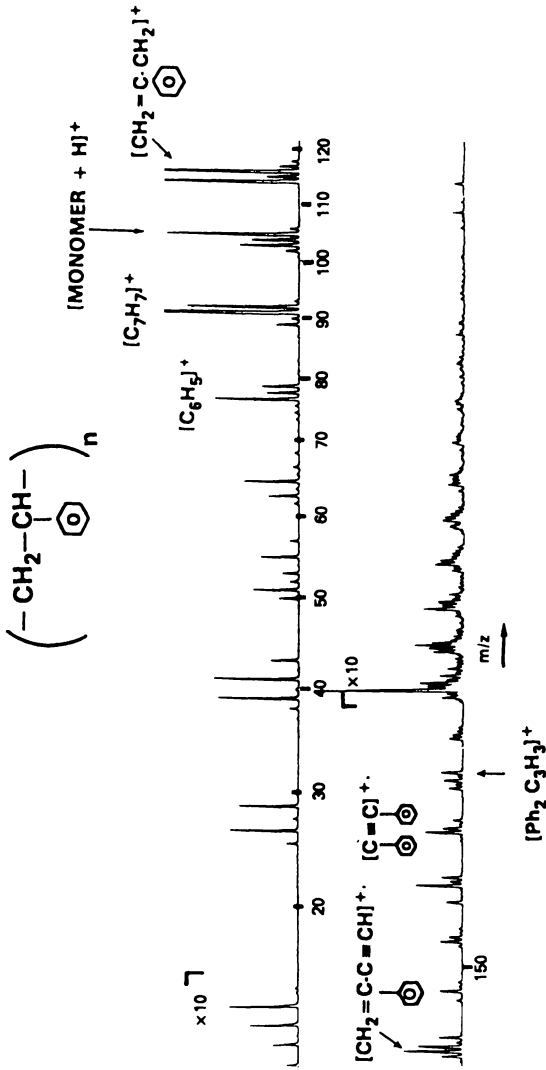
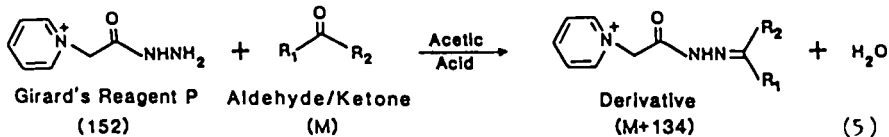


Figure 8. SIMS spectrum of a 0.5 mm thick insulating film of polystyrene cast on silver. Reproduced with permission from Ref. 116. Copyright 1983, Elsevier Science Publishing Co.

Figure 9 shows a commercial drug mixture in human urine underivatized and derivatized with methyl iodide. In Figure 9a the propoxyphene and methamphetamine are not observed from the urine. However, upon derivatization, molecular ions from both can be seen and the ion intensity from methadone and quinine have been increased by a factor of ten.

We have derivatized and observed other drugs such as morphine, codeine, amphetamine, and meperidine with similar results. Cocaine could not be derivatized under the conditions that we employed and was only detected as the protonated molecular ion.

We have also employed other derivatization techniques to selectively label other moieties such as carbonyls and applied these to the selective detection of steroids [119]. Girard's Reagent P reacts with the carbonyl-containing compounds according to Equation 5.



The ions corresponding to the derivatized carbonyl-containing compounds are detected as $[M + 134]^+$, where M is the molecular weight of the aldehyde or ketone.

Steroids such as progesterone, testosterone, and cortisone have been derivatized and analyzed with this method. Cortisone was chosen to demonstrate the enhanced sensitivity obtained with the derivatization/SIMS technique. The SIMS results for underivatized and derivatized cortisone are presented in Figure 10. The ions that are observed from cortisone include the molecular ion $[M + H]^+$ (m/z 361), the silver cationized ion $[M + Ag]^+$ (m/z 467 and 469), and the fragment ion at m/z 407 and 409 corresponding to the loss of the OCH_2OH group.

With 100 ng of cortisone only $[M + Ag]^+$ is observed. The SIMS spectra of derivatized cortisone, on the other hand, show a single peak corresponding to the molecular ion of the derivatized species and an ion of low abundance corresponding to the same fragmentation observed for the underivatized species. The derivatized cortisone was detected at 10 ng with the same signal-to-noise ratio as that for 100 ng of underivatized cortisone, which is approximately an order of magnitude improvement in the detection sensitivity.

Quantitative Analysis. The derivatization/SIMS method can also be applied quantitatively. For example, two ketones, acetone and d_6 -acetone, were mixed in various concentrations in the range of 0.1 to 10 mg/mL and in the ratios of $d_0/d_6 = 10/1, 1/1,$

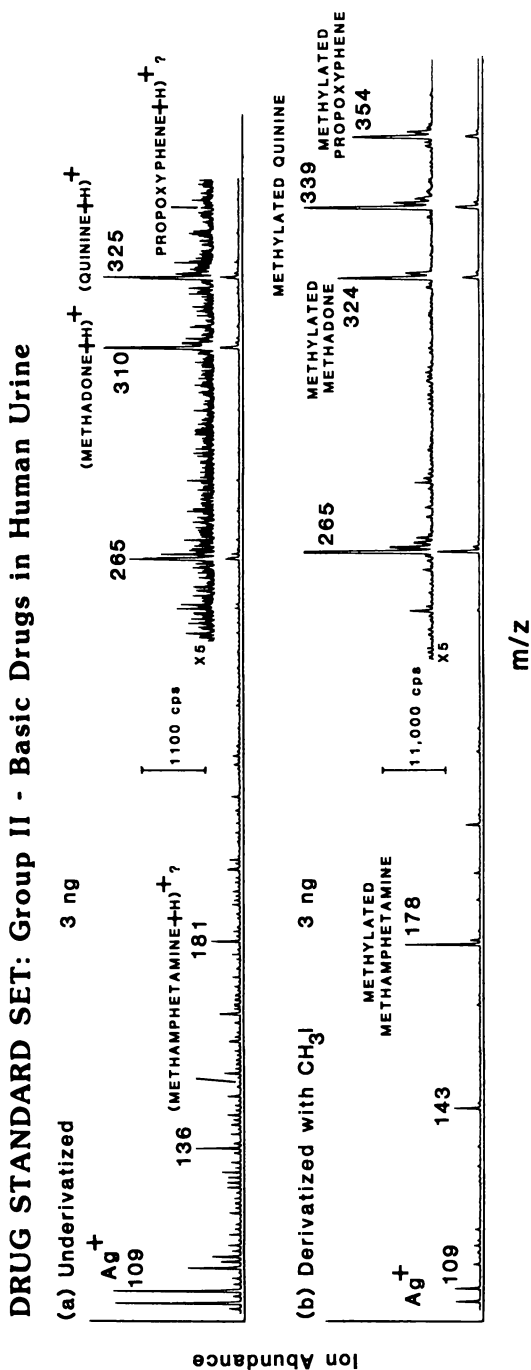


Figure 9. SIMS spectra of an equal mixture of methamphetamine, methadone, quinine, and propoxyphene in human urine. Reproduced with permission from Ref. 118. Copyright 1985, Heyden & Son Ltd. (London).

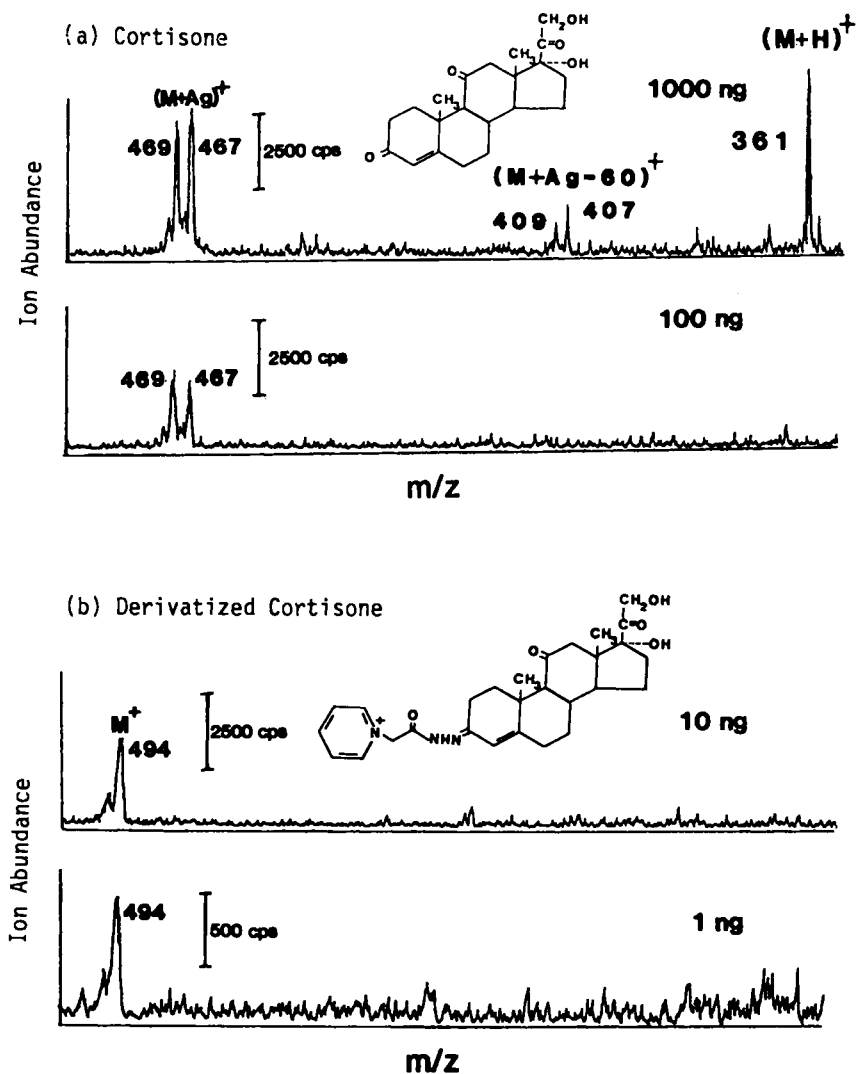
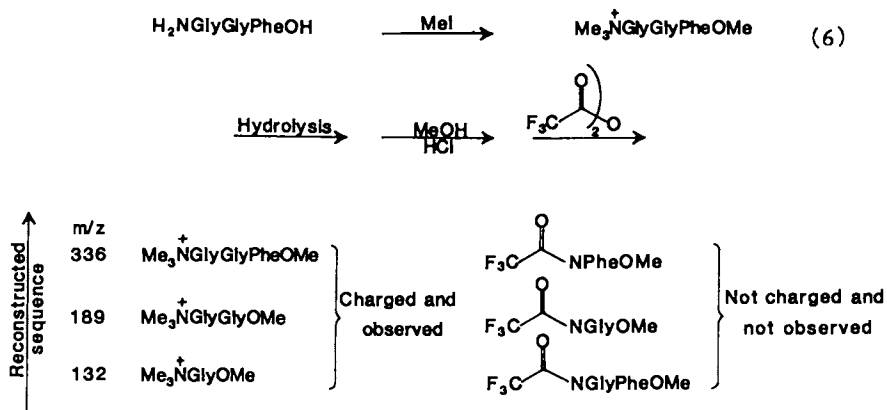


Figure 10. SIMS spectra of a) underivatized cortisone and b) derivatized cortisone.

1/10. Derivatizing the mixture using the Girard's reagent reaction given by Equation 5 produces the results presented in Figure 11 [119]).

It is evident from the spectra that absolute ion abundances cannot be used for quantitation. However, the ion abundance ratio of the two compounds remained constant over the selected concentration range. Therefore, internal standards must be used for quantitation by SIMS. This has been found to be true for fast-atom bombardment mass spectrometry (FABMS), also [124].

Sequencing of Biomolecules. The enhanced detection of charged over uncharged compounds also forms the basis for a method of sequencing of biomolecules [121]. A peptide is selectively labeled at the N- or C-terminus with a charged group (Equation 6), partially cleaved, esterified and acylated, and the mixture examined by SIMS. Only the charged, labeled components in the mixture are observed. Since the charge is due to the label and the label is at only one end, the sequence of the peptide can be readily reconstructed. The spectra of two peptides sequenced from the N-terminus are shown in Figure 12. Only low nanogram levels of each charged species are necessary for detection. It should also be emphasized that the SIMS spectra were taken of the unpurified mixtures.



Our method of enhancing the emission of biological molecules by attaching charged groups has also been applied to oligosaccharides. Sugars are normally only observed with difficulty using SIMS. However, reducing sugars can be readily labeled in aqueous media with Girard's reagents. Once labeled, the sugars can be observed at much lower concentrations than the corresponding underivatized materials. Figure 13 shows the SIMS spectra of underivatized maltose deposited from solution onto a silver surface (Fig 13a), mixed in an ammonium chloride matrix -matrix assisted SIMS - (Fig 13b and c), and derivatized maltose (Fig 13d). The derivatized sugar can be observed at 100 times lower concentrations than the corresponding underivatized material.

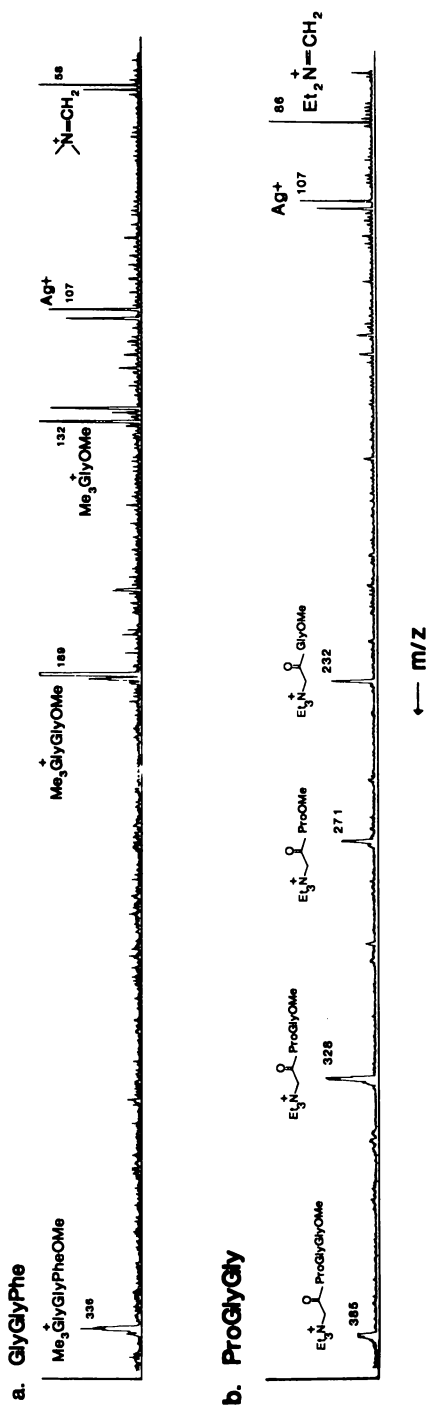


Figure 11. SIMS spectra of the derivatized a) glycyglycyl-phenylalanine and b) prolyglyglycine. Reproduced from Ref. 121.

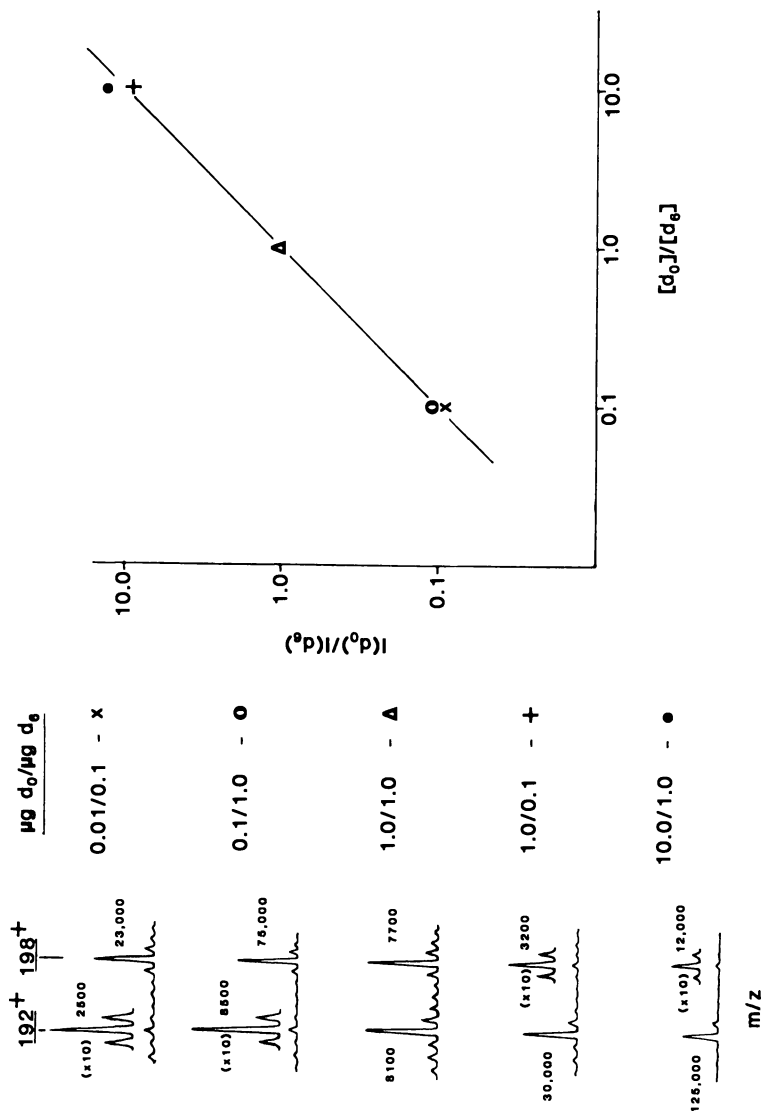


Figure 12. Quantification of d_0 -acetone with d_6 -acetone by derivatization/SIMS. Reproduced with permission from Ref. 119. Copyright 1985, Elsevier Science Publishing Co.

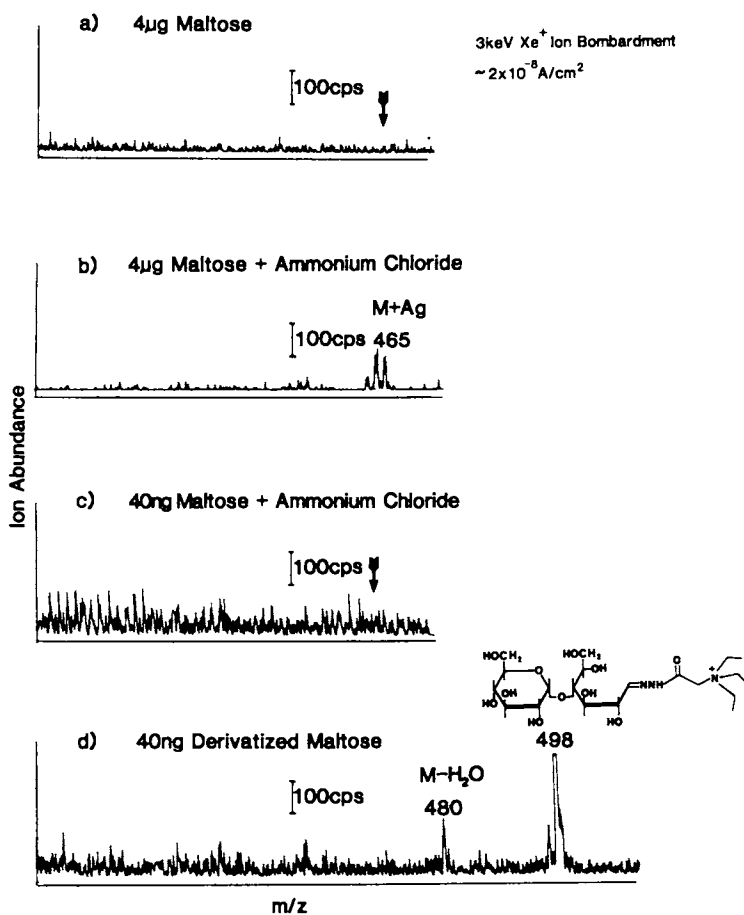


Figure 13. SIMS spectra of maltose and derivatized maltose.

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Fast Atom Bombardment Combined with Tandem Mass Spectrometry for the Study of Collisionally Induced Remote Charge Site Decompositions

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Several classes of FAB desorbed, closed-shell ions have been found to decompose upon collisional activation in an unprecedented manner. The fragmentation occurs for ions with long alkyl chains and involves parallel losses of the elements of C_nH_{2n+2} initiated from the alkyl terminus. The mechanism appears to be a 1,4-elimination of H_2 to give a neutral alkene (C_nH_{2n}) and an unsaturated charged fragment. The reactions do not rely on charge initiation and, as a result, they are termed "remote charge site fragmentations." Considerable structural information may be obtained by interpreting the spectra of daughter ions. The information includes location of double bonds in fatty acids, identification of components in complex lipids, determination of compositions of anionic and cationic surfactants, and identification of long-chained alkyl substituents on phosphonium and ammonium ions.

Fast atom bombardment (FAB) and secondary ion mass spectrometry (SIMS) are important methods for structural determination of compounds. The methods are now being applied to more and more complex substances of biological and commercial interest. These compounds, when desorbed by using particle bombardment, may not give abundant fragmentation. Often, those fragment ions which are formed are difficult to distinguish from matrix ions when liquid matrices such as glycerol are used. Moreover, the compounds may occur as part of mixtures which may be difficult to separate prior to the mass spectrometry determination.

These problems can often be solved by employing a tandem mass spectrometer (MS-MS) as the mass analyzer for SIMS or FAB. The first mass spectrometer serves as a separations device which allows any given desorbed ion to be isolated for further study. Usually the ion is collisionally activated by accelerating it into a

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collision cell containing an inert gas, usually helium. One of the consequences of collisional activation is production of fragment ions which can be separated and detected by using the second mass spectrometer.

A few years ago, we began a research program to develop methods of analysis which would involve the use of FAB and a high performance tandem mass spectrometer. The tandem instrument was the first triple sector mass spectrometer to be designed and built by a commercial instrument company (Kratos of Manchester, U.K.). The first mass spectrometer of the combination is a double focussing Kratos MS-50 which is coupled to a low resolution electrostatic analyzer, which serves as the second mass spectrometer (1). This FAB MS-MS combination has been used to verify the structures of an unknown cyclic peptide (2), a new amino acid modified by diphtheria toxin (3), and an ornithine-containing lipid (4). A number of methods have also been worked out which rely on this instrumentation. They include the structural determination of cyclic peptides (5), nucleosides and nucleotides (6), and unsaturated fatty acids (7) and the analysis of mixtures of both anionic (8) and cationic surfactants (9).

In this chapter, we have chosen to review the results obtained in studies of the collisional activation of saturated and unsaturated fatty acid carboxylates and other related anionic substances such as sulfates and sulfonates. We will show that these kinds of compounds undergo a unique set of fragmentation reactions which occur remote from the charge site. Results which point to the mechanism of the reactions and to possible analytical applications, particularly the study of surfactants, will also be reviewed. These reactions are not reserved for negative ions only; certain positive ions also undergo remote charge site fragmentations. Our intention is to discuss in some detail one class of decomposition reactions in order to show the interesting chemistry which can be exhibited by gas-phase ions desorbed by particle bombardment. Moreover, we hope that the discussion will help stimulate new developments in desorption ionization which will permit investigations of this nature to be conducted on higher mass ions and lower quantities of chemical compounds.

Description of the Phenomenon

Fast Atom Bombardment (10) is an effective desorption method for many molecules of biological interest such as long chained fatty acids. In the negative ion mode, the FAB spectra of typical fatty acids show principally $(M-H)^-$ ions. The palmitic acid spectrum in Figure 1 is a representative example. Even under conditions of high multiplier gain and magnification, convincing evidence for additional fragmentation is lacking in spectra acquired into a computer at slow scan rates of 30 sec/decade.

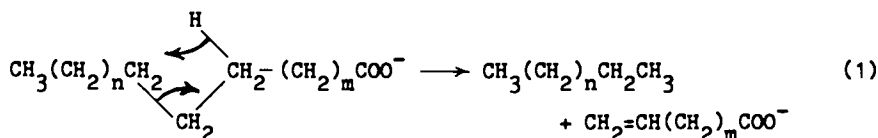
While the spectrum shown in Figure 1 may be very useful in many applications, it does not reveal structural information. In many cases, such information may be obtained by studying the metastable decomposition of major ions. The instrument used in this laboratory may be operated in a manner in which an ion such as the $(M-H)^-$ ion of the fatty acid is selected, even at high resolution if necessary, by using MS-I and its decompositions in the field free region between MS-I and MS-II followed by scanning the second ESA (MS-II). However, the metastable decompositions of the $(M-H)^-$ ions of the

fatty acids we have studied involve only a very low abundance water loss. This loss is only apparent for acids with chains of 16 carbons or more, and then the relative abundance of the appropriate metastable ions decomposing in the third field free region is a factor of 60,000 smaller than the abundance of the (M-H)⁻ ion.

However, high energy collisional activation (11,12) of carboxylate anions such as the (M-H)⁻ ion of palmitic acid, in an MS/MS experiment causes fragmentation as shown in Figure 2A. This distinctive and highly reproducible pattern is found for carboxylate anions with a carbon chain length of at least six or seven atoms and is well-defined for those anions containing 10 carbon atoms or more. The decompositions observed may be formally described as a series of parallel alkane losses from the (M-H)⁻ ion. Also observed are losses which lead to ions m/z 58 and m/z 86 and the loss of water. These decompositions occur for 1-2% of the collisionally suppressed ion beam. The series of parallel losses of the elements of neutral alkanes is a particularly unique feature. While the losses of neutral alkane fragments have been reported by several groups for a variety of compounds which include secondary alcohols, ketones, amines, and quaternary ammonium ions (13-19) these losses are associated with specific rearrangements at the charge site and are not part of a series of alkane losses. Another noteworthy feature of the CAD spectra is the abundance of high mass fragment ions. Stenhagen's classic studies of long chain carboxylate ester radical cations (20-22) show that fragmentations occur which favor the formation of low mass ions.

Mechanism. The abundance of high mass ions combined with the expectation that the charge should reside at the carboxylate site, suggest that the losses of the elements C_nH_{2n+2} preferentially occur from the end of the carbon chain remote from the carboxylate. This assumption was shown to be valid for the CH₄ loss from palmitic acid by comparing the CAD spectra of the (M-H)⁻ ion of unlabeled palmitic acid with the spectra of the (M-H)⁻ ion of 16,16,16-d₃-palmitic acid (Fig. 2). The two spectra differ only in the mass of the (M-H)⁻ ion. All other ions have the same m/z values indicating that indeed the CH₄ loss is from the alkyl terminus of the palmitate anion. Studies of other labeled carboxylic acids (23,24) including 7,7,8,8-d₄-palmitic acid, 9,10-d₂-myristic acid, 9,10-d₂-stearic acid, 2,3-d₂-octanoic, 9,10,12,13-d₄-stearic acid, 9,10,12,13,15,16-d₆-stearic acid, 4,5,7,8,10,11,13,14,16,17,19,20-d₁₂-docosahexanoic acid, and 5,6,7,8,11,12,14,15-d₈-eicosanoic acid, provide additional supporting evidence for the mechanism of this process.

The pattern of apparent alkane losses from specifically deuterated carboxylate ions is most easily rationalized by invoking a 1,2-elimination mechanism (see Equation 1)



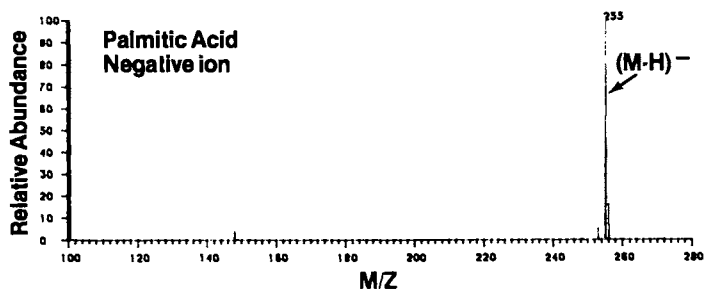


Figure 1. Negative ion mass spectrum of the FAB desorbed palmitic acid. Ion m/z 148 is from the triethanolamine matrix.

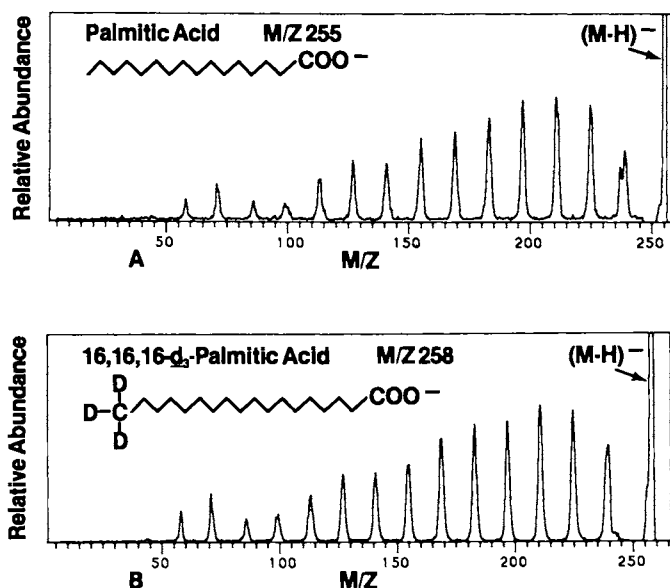
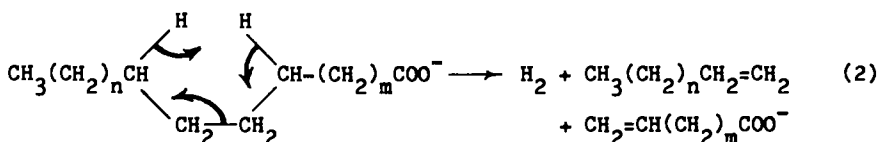


Figure 2. Spectra of the daughter ions produced by collisionally activating the $(M-H)^-$ ions of unlabeled palmitic acid (A) and 16,16,16-d₃-palmitic acid (B). Note the spectra differ only in the mass of the main beam.

For example, upon collisional activation, 7,7,8,8- d_4 -palmitic acid loses unlabeled C_2H_{2n+2} from CH_4 to C_6H_{14} . However, the losses of seven and eight carbons are as $C_7H_{15}D$ and $C_8H_{17}D$. These losses of $C_7H_{15}D$ and $C_8H_{17}D$ are greater than 90%; i.e. less than 10% losses of C_7H_{16} or C_8H_{18} occur. This was most clearly established by using the NIEHS four sector mass spectrometer which has the capability for unit resolution of MS-II (we acknowledge Dr. Ron Hass for allowing us this opportunity).

The 1,2-elimination mechanism as shown in Equation 1 is a four-electron orbital symmetry forbidden process (25). Therefore, an alternative mechanism, such as the allowed six electron process shown in Equation 2, may be more likely. If the reaction proceeds in this manner, a terminally unsaturated fatty acid carboxylate will be formed just as for the 1,2-elimination. The deuterium labeling



results will be the same for this mechanism as for that shown in Equation 1; that is, deuterium labeling will not permit us to distinguish between the mechanisms shown in Equations 1 and 2. The neutral products of the reaction will be hydrogen and an alkene, which, of course, cannot be distinguished mass spectrometrically from the alkane product required if the mechanism in Equation 1 is correct.

In addition to mechanism considerations, several other generalizations can be made regarding the collisionally-induced dissociation of the long chained acids. The first is that this unique fragmentation behavior occurs for closed-shell carboxylate anions. The second is that the initiation of fragmentation remote from the charge site is a significant departure from the well-accepted charge-site or radical-site initiation of decompositions of gas-phase ions. The role of the charge site may be reduced due to the fact that this fragmentation appears to resemble a high energy thermal process. Evidence for this includes the fact that a series of parallel C_nH_{2n+2} losses occur in the pyrolysis of fatty acid esters. For example, Sun *et al.* have shown that the pyrolysis of 9,10- d_2 octadecanoate (26) leads to production of a series of alkenes and unsaturated fatty esters. The relative abundances of the various unsaturated esters are comparable with the abundances of the product ions that we see in the CAD spectrum. The 1,4-elimination mechanism proposed above is entirely consistent with the results from the thermolysis studies.

Other evidence that the fragmentation is a high energy process is found by obtaining mass spectra at a higher dynamic range than was employed for the full scan mass spectra discussed earlier. In the mass range m/z 224 to the molecular ion, ions m/z 225, 237, and 239 were seen with abundances of 0.64%, 0.29%, and 0.81% with respect to the $(M-H)^-$ ion at m/z 255. These ions correspond to the losses of C_2H_6 , water and CH_4 , respectively. Under normal FAB conditions, one expects the desorbed ions to have an energy

distribution with at least a small number of ions of relatively high energy. As the narrow scan data indicate, a small fraction of the desorbed ions possess sufficient energy to undergo these remote charge site fragmentations. The phenomenon becomes much more apparent after high energy collisional activation.

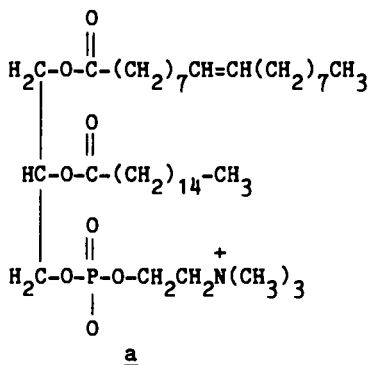
Evidence for Remote Site. Losses of the elements C_nH_{2n+2} could occur remote from the charge site but still result from coiling (27) of the molecule to allow interaction between the alkyl chain and charge site. Evidence that coiling is not necessary for the reaction to occur was provided by examining the collisionally activated decomposition of the $(M-H)^-$ ion of cholesteryl hemisuccinate (Fig. 3), a rigid molecule. In this case C_nH_{2n+2} losses occur from the alkyl chain remote from the charge-bearing carboxylate. Analysis of a molecular model indicates that a minimum length of seven carbons in the alkyl chain is necessary for any interaction with the charge site. The lack of aromatic character or multiple double bonds in the steroid moiety are taken to discount the possibility of charge dispersion by resonance effects.

The CAD spectrum of the $(M-H)^-$ ion of cholesteryl hemisuccinate (Fig. 3) also illustrates one specific type of structural information which can be obtained from the remote loss pattern. The collisionally activated $(M-H)^-$ ions decompose by losing CH_4 , a major fragmentation, and then the elements of C_2H_8 , but virtually no loss of C_2H_6 occurs. This is readily explained in terms of the structure of the alkyl chain. Since there is a methyl branch at the end, increased probability for CH_4 loss and, according to the above mechanisms, reduced probability for C_2H_6 loss are expected. Hence, branch points in a carbon chain may be identified by the suppression of specific C_nH_{2n+2} losses. As indicated in this spectrum, remote losses resume once the branch point is passed; *i.e.* C_3H_8 and C_4H_{10} losses occur as expected.

Strategy for Locating Double Bonds. A structural feature revealed by the series of C_nH_{2n+2} losses from collisionally activated ions is the presence and location of a double bond in the alkyl chain of a carboxylate anion (7). This would be expected from either a 1,2-elimination mechanism proposed in Equation 1 or a 1,4-elimination of H_2 (Equation 2) as the transfer of vinylic hydrogens and cleavage of the double bond are not anticipated. The double bond is located by the absence of specific C_nH_{2n+2} losses. The collisionally activated decompositions of 9-hexadecenoic acid gives rise to a typical spectral pattern (Fig. 4). Two abundant ions (A and A') are followed by three very low abundance ions at lower mass and then a third abundant ion (B). The abundant ions A and B arise from a hydrogen transfer and cleavage of the two C-C allylic bonds, one on the acid side and the other on the hydrocarbon side. Alternative and more likely mechanisms are given in Equations 3 and 4. The first mechanism depicts C_nH_{2n+2} loss remote from the double bond; the second shows the facile allyl-cleavage/rearrangement. Both should be thermally allowed.

selected using MS-I of the tandem mass spectrometer and cleanly collisionally activated. The CAD spectrum can be found in reference 23. Alkane losses involving the incorporation of one deuterium are first found as the losses of C_4H_9D and $C_5H_{11}D$. According to the mechanisms, the most remote double bond from the carboxyl end must be at position 14. Similarly, losses of $C_7H_{13}D_3$ and $C_8H_{15}D_3$; $C_{10}H_{17}D_5$ and $C_{11}H_{19}D_5$; and $C_{13}H_{21}D_7$ and $C_{14}H_{23}D_7$ are interpreted to locate the other three double bonds at positions 11, 8, and 5, respectively.

Application to Complex Lipids. Structural information may be obtained for complex lipids as a result of remote charge site fragmentation (23). The negative ion FAB spectra, as well as the collisional activation spectra of the major ions, have been obtained for a number of phospholipids, including phosphatidylcholines, phosphatidylserines, phosphatidylinositols, cardiolipid, phosphatidylethanolamine and phosphatidylglycerol. In the case of phosphatidylcholines, for example, the full scan FAB spectra show that three high mass ions are formed which correspond to losses of various portions of the choline. In addition, ions which may be attributed to carboxylate anions from the fatty acid chains are also observed. For α -phosphatidylcholine, β -stearoyl- γ -oleoyl (structure a), the principal ions of the FAB spectra are m/z 773, 728, 702, 283, and 281. The constituent fatty acid carboxylates are the most abundant ions formed in the decomposition of the desorbed lipid. Collisional activation indicated that these anions originate via decompositions of the three high mass ions. By collisionally activating the m/z 281 ions and comparing the CAD spectrum of the fragments of m/z 281 formed from the lipid with those of the $(M-H)^-$ of authentic samples of oleic and vaccenic acids it could be confirmed that one of the fatty acid constituents was oleic and not vaccenic acid, for example. As expected, the CAD



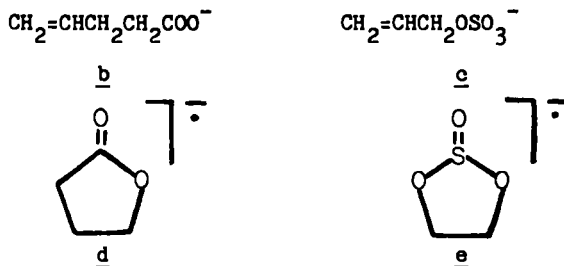
spectra of oleic acid and the m/z 281 ion from the lipid are characterized by suppressed fragmentations corresponding to C_8H_{18} , C_9H_{20} and $C_{10}H_{22}$ losses. For vaccenic acid, fragmentations which lead to expulsion of C_6H_{14} , C_7H_{16} , and C_8H_{18} are suppressed.

Application to Other Negative Ions. Remote charge site fragmentation and its utility for revealing structural information are not limited to carboxylate anions. Other classes of anions including alkyl sulfates, alkyl ether sulfates, alkyl sulfonates, and n-acylated amino acids can be desorbed as $(M-H)^-$ and collisionally activated to undergo C_nH_{2n+2} losses. All of these compounds possess the common features of long alkyl chains and stable, highly localized anionic sites.

Many of these substances have substantial commercial significance as surfactants. The wide range of compounds found in any given surfactant creates a challenging problem if one wishes to analyze it. The nature of the mixtures is often obscure as the raw materials are invariably mixtures of fatty acids, alcohols, or hydrocarbon precursors. Lyon *et al.* (8) have demonstrated that FAB combined with MS/MS can be used to deal with these mixtures.

The analysis of a mixture of alkylsulfonates is representative of the success of this approach (8). The CAD spectrum of a FAB-generated molecular anion of an alkylsulfate, such as hexadecyl sulfate (Figure 5), allows one to verify that the material is a sulfate (ions m/z 80 and 96 which are SO_3^- and SO_4^- , respectively), to obtain the length of the carbon chain by counting peak manifolds from m/z 96 to the molecular ion, and to verify that the alkyl group is normal (not branched). The peak manifolds correspond to ions formed by remote charge site C_nH_{2n+2} losses. The losses are comparable with those seen for carboxylates (Fig. 2). In addition, the basic pattern of relative abundances is similar; i.e. C_3H_8 loss most favored with a decrease for more complex C_nH_{2n+2} .

It appears for both carboxylates and sulfates that the remote charge site fragmentation is first seen when the product ion has a chain length of four atoms attached to the charge site. For fatty acids, the series begins at m/z 99 (see structure b), and for sulfates, it starts with m/z 137 (see structure c). Ions m/z 86 for carboxylates and m/z 124 for sulfates are analogs. Both are presumably 5-membered ring radical anions which contain the functional group (structures d and e). A difference between the sulfates and carboxylates is the loss of water which occurs only for the carboxylate anion. This decomposition is probably not a remote charge site reaction.



As for the carboxylates, the remote site fragmentation is much more pronounced with increasing carbon chain length. For example, fragmentation is seen for octyl sulfate but is much more pronounced for longer-chained sulfates such as hexadecyl sulfate.

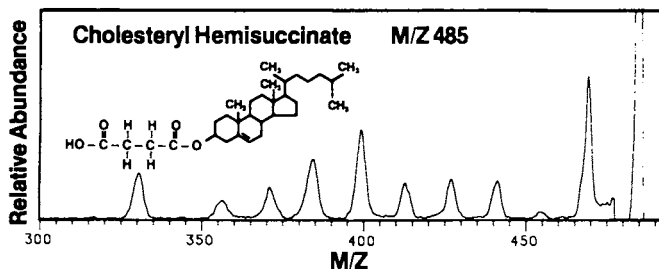


Figure 3. CAD spectrum of the negative ions from the dissociation of cholesteryl hemisuccinate $(M-H)^-$ m/z 485. Expanded portion of the spectrum in the mass range m/z 300 to m/z 500 is shown.

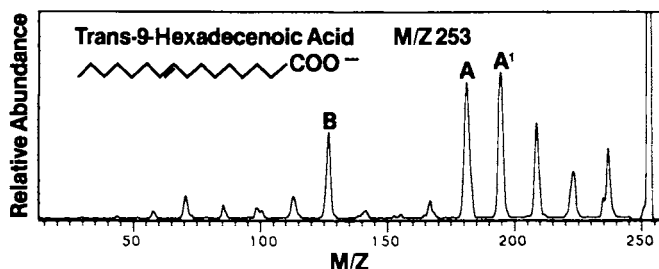


Figure 4. Spectrum of the daughter ions produced by collisionally activating the $(M-H)^-$ ions of trans-9-hexadecenoic acid.

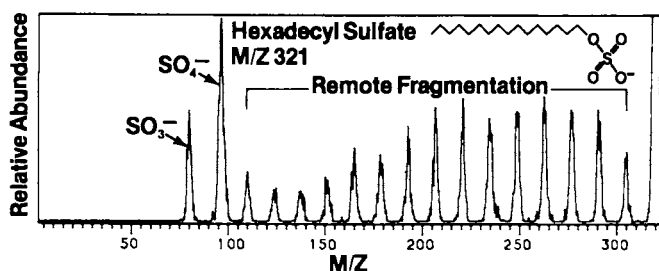


Figure 5. Spectrum of the daughter ions produced by collisionally activating the $(M-H)^-$ ions of hexadecyl sulfate.

Nevertheless, the octyl sulfate CAD spectrum yields sufficient information to allow the compound to be distinguished from isomeric 2-ethylhexyl sulfate (for a comparison, see ref. 8). The branching of the 2-ethylhexyl sulfate causes suppression of fragmentation at the branch point in a fashion analogous to that seen for the carboxylates and for the steroid (see Figure 3).

Analysis of an alkyl ether sulfate surfactant further exemplifies the utility of the FAB MS/MS techniques for dealing with complex mixtures (8). The negative ion FAB spectrum contains a series of ions separated by 44 amu starting with m/z 265, the lowest mass ion of significant abundance, and continuing in a regular pattern to m/z 705. Additional homologous series differing by 14 amu are also observed. Selection and collisional activation of any of these ions produced consistent CAD spectra with two features: a C_nH_{2n+2} loss series and an equally well-defined repetitive pattern which could be attributed to each ethylene oxide unit (8). It was apparent from the CAD spectra and the relative abundances of the parent ions that the mixture included a series of dodecyl ether sulfates containing one to ten ethylene oxide units. Those with one to four units were found to be the most abundant. Other constituents containing tridecyl, tetradecyl, and pentadecyl alkane moieties gave ions which were superimposed on this dodecyl series. The remote C_nH_{2n+2} loss pattern of the respective CAD spectra allowed for identification of alkyl homologs.

The MS/MS approach to the analysis of surfactant mixtures seems to be applicable to most types of anionic surfactants (8). While each class exhibits certain unique fragmentations, which depend on the functional groups present, the characteristic negative ion CAD spectra reveal structural information pertaining to alkyl chain length and branching for all cases studied thus far except sulfosuccinates.

In cases of extensive branching, as for the alkylbenzenesulfonates, the C_nH_{2n+2} loss series is significantly perturbed compared to the straight chain alkyl sulfates, but it is sufficiently abundant to show perturbations in the loss pattern. These perturbations may be interpretable for identifying branch points. N-Acylated amino acids also show a suppressed remote charge site loss series because the preferred fragmentations are the decarboxylation of the parent anion and formation of the carboxylate anion of the amino acid (8).

Application to Ammonium and Phosphonium Ions. The remote charge site parallel C_nH_{2n+2} loss fragmentations are not limited to negative ions but have also been observed as a result of collisional activation of positive ions, including those formed from long chained amines, quaternary ammonium compounds, and phosphonium salts. These substances also share the common features of long alkyl chains and stable, closed-shell charge sites.

While remote site fragmentations are often the dominant decompositions of negative ions, positive ions usually undergo additional types of fragmentations. The CAD spectrum of hexadecylamine (Fig. 6) is a typical example of the spectra obtained for the $(M+H)^+$ ion of long chained amines. Ions at m/z 100 or greater result from fragmentations in which C_nH_{2n+2} segments are

expelled. This set of fragmentations is analogous to that seen for the anions discussed previously in this chapter. Although they are of low abundance, the ions may be used to determine chain length by counting the number that appear in the CAD spectrum (9).

As illustrated in Figure 6, two other types of fragmentation are observed for collisionally-activated ammonium ions. The most abundant products are alkyl and alkenyl cations which have three to five carbon atoms. These presumably result from fragmentation of higher mass aliphatic carbocations to yield the alkyl series of C_nH_{2n+1} (m/z 43, 57, 71, etc.) and the alkenyl series of C_nH_{2n-1} (m/z 41, 55, 59, etc.). For saturated, long-chained amines, the predominant ions are of the alkyl series, but the presence of a double bond causes the most abundant series to be alkenyl ions (9). The third fragmentation pathway yields nitrogen containing ions, namely NH_4^+ (m/z 18) and $CH_2NH_2^+$ (m/z 30), and in some cases m/z 44. This is in sharp contrast with the decompositions of amine radical cations which lead principally to formation of nitrogen-containing fragments.

The information from a full scan FAB spectrum and from CAD spectra of selected ions may be used, as for the anions to analyze a mixture and to obtain specific structural identifications. For example, the positive ion FAB spectrum of dimethyldi-(hydrogenated tallow)ammonium chloride has dominant ions at m/z 550, 552, 492, 466, and 438, which indicate that it is a mixture (9). Collisional activation of each of these ions, as shown for the m/z 494 ion in Figure 7, reveals structural information. The increased prominence of the remote site C_nH_{2n+2} loss fragmentation for dimethyl quaternary ammonium ion as compared to amines (Fig. 6) is both interesting and useful. For example, counting the number of fragment ions (Fig. 7) from the molecular ion (m/z 494) to ions m/z 296 (A), m/z 268 (B), and m/z 240 (C), reveals that losses of $C_{14}H_{30}$, $C_{16}H_{34}$ and $C_{18}H_{38}$, respectively, occur from the parent ion. Since these ions terminate the prominent remote charge site loss series, it is concluded that the mixture contains two dimethyl dialkyl ammonium ions of the general formula $(CH_3)_2N^+R_1R_2$ where, for one constituent, R_1 and R_2 are both hexadecyl and for the other, R_1 and R_2 are tetradecyl and octadecyl.

Mixtures of more complex nitrogen-containing compounds such as amine oxides and ethoxylated quaternary amines are also amenable to the type of investigation described above (9). The CAD spectra of these substances are dominated by a few informative ions which result from specific fragmentations characteristic of the class of compounds. The C_nH_{2n+2} loss series also occurs but at a less abundant level for the ethoxylated compounds, and the series is of low abundance for the amine oxides.

Another class of positive ions which undergo C_nH_{2n+2} losses remote from the charge site are triphenyl alkyl phosphonium salts. Collisional activation of *n*-decyl triphenyl phosphonium ions desorbed directly by using FAB results in formation of daughter ions which include a prominent ion m/z 262 attributed to $(C_6H_5)_3P^+$ and a set of ions in the range m/z 300-387 formed by C_nH_{2n+2} losses (Figure 8). A study of the dependence on translational energy revealed that at high collision cell potentials (low collision energies of a few hundred volts), remote site fragmentation is

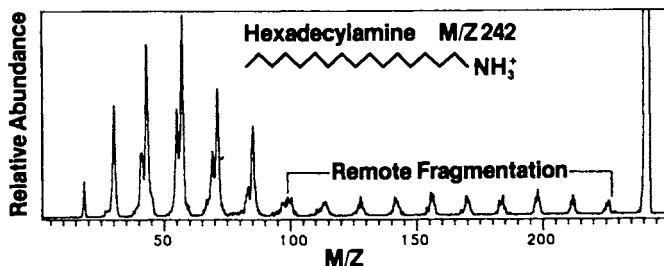


Figure 6. CAD spectrum of the decomposition of the $(M+H)^+$ ion of hexadecylamine.

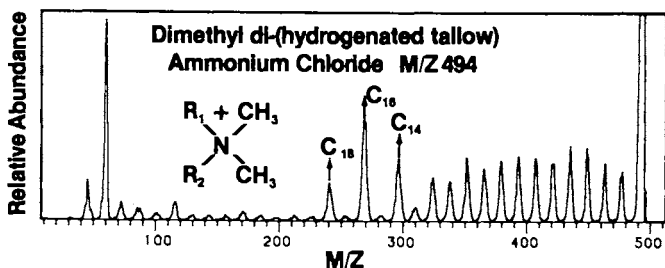


Figure 7. CAD spectrum of the positive ions from the dissociation of dimethyl di-(hydrogenated tallow) ammonium chloride m/z 494. This is a mixture of two dimethyldialkylammonium ions where R_1 and R_2 are C_{14} and C_{18} or both C_{16} .

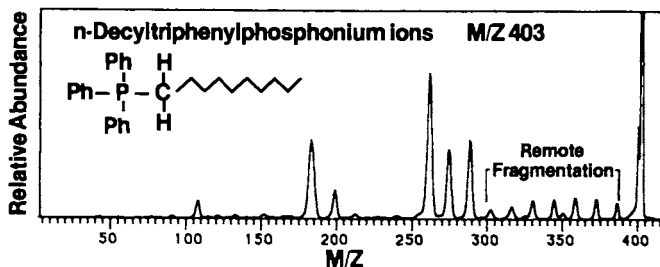


Figure 8. Spectrum of the daughter ions produced by collisionally activating positive n-decyltriphenylphosphonium ions m/z 403.

difficult to observe. However, it becomes an increasingly significant feature of the CAD spectrum as the collision energies are raised to kV levels (30).

Conclusion

Parallel losses of a series of fragments of the elements C_nH_{2n+2} from collisionally activated, closed-shell, long-alkyl chained ions is a wide-spread phenomenon. As shown, this type of fragmentation can be used to reveal structural features such as alkyl chain length and sites of branching and double bonds. Because the fragmentation requires high energy and does not rely on the charge site, we suggest that these decompositions constitute a new class of reactions not previously observed in mass spectrometry.

The fragmentation of cholesteryl hemisuccinate is a clear illustration that the phenomenon occurs physically remote from the charge site and that charge migration to the alkyl chain is apparently not important. Moreover, the ammonium ions, which have a covalently saturated charge sites, also show remote charge site fragmentation. The reactions of ammonium ions serve as further support for the idea that transitory charge on the alkyl chain, formed by hydrogen transfer to the charge site, does not initiate the fragmentation.

Improvements in SIMS and FAB which lead to more intense ion beams are highly desirable because that will permit the information to be obtained for smaller samples and for lower abundance constituents in complex mixtures such as surfactants. Moreover, consecutive activation steps (MS/MS/MS) should be important in investigations of mixtures of complex lipids and related materials. Here one step of collisional activation is necessary to liberate the fatty acid carboxylate and a second step is required to activate the anions. These experiments also require intense ion beams. It is our hope that the analytical possibilities raised by the chemistry discussed here will stimulate further research to improve FAB and SIMS.

Acknowledgments

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Analysis of Reactions in Aqueous Solution Using Fast Atom Bombardment Mass Spectrometry

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Fast atom bombardment mass spectrometry has been utilized for the quantitative determination of ionic species, in glycerol/water solutions, which are produced by chemical and enzymic reactions. It is shown that reaction constants can be determined in this manner and that they can be accurately related to those determined by other methods used in the analysis of aqueous solutions. The reactions studied include proton dissociation constants for organic acids, an enzyme equilibrium constant, and enzyme rate constants using natural substrates.

Fast atom bombardment mass spectrometry (FABMS) has become an important addition to the ionization techniques available to the analytical chemist in recent years. It has been particularly useful in a number of diverse applications which include molecular weight determinations at high mass, peptide and oligosaccharide sequencing, structural analysis of organic compounds, determination of salts and metal complexes, and the analysis of ionic species in aqueous solutions. This paper will focus on some aspects of the quantitative measurement of ionic species in solution. The reader is referred to a more comprehensive review for more details of some of the examples given here as well as other applications (1).

One of the important questions with regard to the use of FABMS in following ionic reactions is whether the technique can accurately sample the ionic species in solution so as not to perturb the chemical dynamics which exist at that point in time, i.e., will the ions which are measured in the gas phase have the same ionic distribution as they had in the aqueous phase. If so, then under what conditions do these considerations hold?

A number of recent studies have shown that under certain conditions, FABMS indeed can very accurately measure the balance of ionic species in ongoing chemical reactions in solutions. These studies include the determination of acid dissociation constants (2), equilibrium constants for enzyme catalyzed reactions (1), metal-ligand association constants (3), and measurements of

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reaction rates for specific substrate-enzyme reactions (4). Several of these applications will be discussed in this paper.

Acid Dissociation Constants

Early work with aqueous solutions containing ionic solutes in a 1:1 mixture of water and glycerol showed that factors such as the pH of the solution and salt content had significant and reproducible effects on the distribution of ionic species measured by the mass spectrometer. Using the Henderson-Hasselbalch equation under simplifying conditions (at low ionic strengths with acid components whose pKa's lie between 3 and 10), it was shown that the pKa of an acid could be accurately determined knowing the pH of the solution and the concentrations of acid and base species (2). With respect to the measurement of this constant by FABMS,

$$pK_a = pH + \log \frac{(HA+H)^+}{(ANa+H)^+ + (ANa+Na)^+}$$

where $(HA+H)^+$ is the ion intensity of the undissociated acid HA, and $(ANa+H)^+$ and $(ANa+Na)^+$ are the ion intensities of the corresponding conjugate base A. For example, the shift in the molecular ion species as a function of pH is shown in Figure 1 for the zwitterionic compound tris(hydroxymethyl)methylaminopropanesulfonate (TAPS). As the pH is lowered below the pKa of the acid, the protonated form of the compound predominates. Further, the quantitative shift of ion current can be described mathematically according to established equations. Since these measurements were performed in 50% glycerol solutions, one directly calculates the pKa' (G50) for the acid, that is, an apparent pKa at a given ionic strength in a solution containing 50% glycerol. In order to compare this value with those reported in the literature, usually expressed as pKa, it is necessary to apply corrections for the effect of ionic strength and the dielectric constant difference between the aqueous glycerol solution and water. The magnitude of these two effects can be determined experimentally; a plot of the apparent pKa vs ionic strength gives a straight line which can be extrapolated to zero ionic strength and a plot of apparent pKa vs glycerol content extrapolated to zero glycerol content. With these corrections, the pKa's of several types of acids were measured and compared with published values. For twenty-five different acids, the average deviation of the value for the pKa determined by FABMS with respect to those reported in the literature was approximately ± 0.05 pKa units.

In further work involving the measurements of acidity constants by FABMS, it was found that the measurements of pKa's could be applied in a qualitative manner using the Born equation (5) to calculate the average ionic radii of the acid and base species in solution. A modified form of this equation follows (6),

$$(pK_a)_s - (pK_a)_w = \frac{122n}{D_s} (1/D_s - 1/D_w)$$

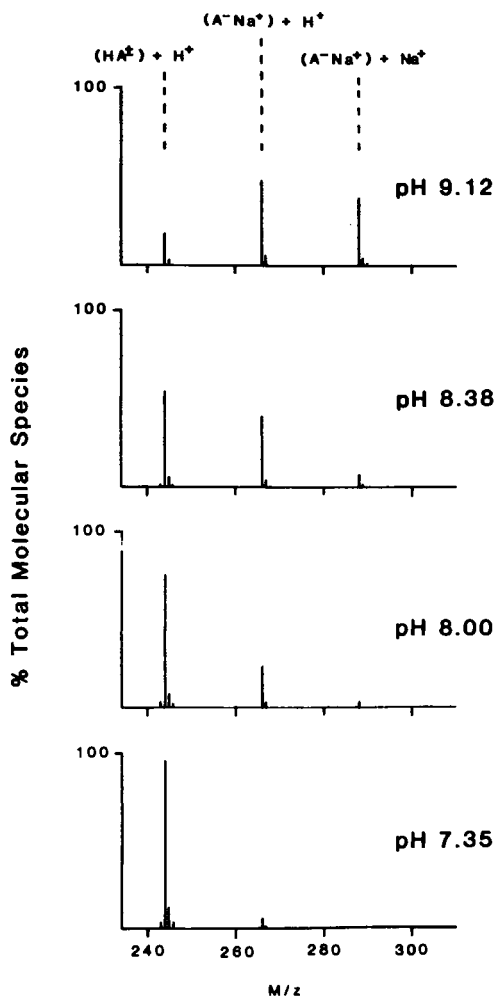


Figure 1. Effect of pH on the molecular ion species of solutions of TAPS [tris(hydroxymethyl)methylaminopropanesulfonic acid] in 50% glycerol/water. HA represents the protonated amine, a zwitterion of molecular weight 243, and A^- the conjugate base formed from dissociation of a proton from the acid. Reproduced from Ref. 2. Copyright 1983, American Chemical Society.

where the subscripts s and w refer to the values of the appropriate constants in solvent and water, respectively, n is the charge number, and r the average ionic radii of the ions. Essentially, the equation shows that the change in the value of the pK_a of a given acid in a solvent relative to that in water is a function of the charge of the various species, the radius of the ions, and the difference in the dielectric constant of the two solvents. However, the equation is not quantitative because it fails to take into account several important factors, one of which is the energy of solvation of the various ionic species. Nevertheless, the ionic radii calculated from the pK_a shift were found to approximate a straight line for the mass range 50-500, with an acid of molecular weight 100 having an ionic radius of approximately 2 angstroms and that of molecular weight 400, approximately 7 angstroms. The importance of these data lies not so much in the specific values measured, but rather in the fact that they show that under specified conditions the bombardment process does not substantially disrupt the balance of ionic species so that the gas phase ionic distribution is similar to that which existed in the liquid phase. Further, these distributions can be predicted from considerations derived from classical approaches.

Several factors appear to be important for the accurate measurement of ionic components in aqueous solutions by FABMS. First, the glycerol content can generally be varied between 40 and 70%; below 40% evaporation of the water from the FAB probe tip is too rapid to obtain reproducible data and above 70% the dielectric constant change is sufficiently large so as to significantly alter the acidity scale and ionic interactions. Second, it is essential that sufficient concentrations of counterions are present so that charge pairing can occur, for example, all A^- ions should be paired to give $A^-.Na^+$. If not, the base species will be inadequately collected in the gas phase analysis by an instrument set up to collect positively charged ions. Third, multiple positive charges on a molecule can cause difficulty since these are generally more weakly charge paired and lose a positively charged fragment either in the process of sputtering from the sample surface or from fragmentation prior to analysis.

Enzyme Reactions

Other types of reactions which have been studied using FABMS include those catalyzed by enzymes. This application is particularly interesting because it represents for the first time a generally useful and molecularly specific probe with which to measure a wide variety of enzyme substrates and products. Two approaches have been successful, one in which the reaction is followed by the removal of aliquots of sample taken at timed intervals with subsequent analysis by FABMS and the other allowing the reaction to take place in a glycerol-water mixture on the probe directly inside the mass spectrometer. The choice of either method depends upon the application. If the prime interest is to analyze a substrate, for example, monitoring the release of amino acids from a polypeptide using an exopeptidase, then direct analysis inside the spectrometer may be preferred. If, on the other hand, the prime interest lies

in obtaining kinetic data for a particular enzyme-substrate reaction, then analysis of a batch reaction where aliquots are removed at timed intervals would be the better approach.

A number of enzymes have been shown to retain considerable activity in aqueous-glycerol solutions and, further, can retain this activity under intermittent bombardment with high energy neutral atoms. These include trypsin, chymotrypsin, dipeptidyl peptidases, proline specific endopeptidase, V8 protease, and carboxypeptidase Y (4,7). Figure 2 shows the FAB mass spectrum of the digestion products of the hydrolysis of the peptide β -caso-morphin (Tyr-Pro-Phe-Pro-Gly-Pro-Ile) by the enzyme proline specific endopeptidase. The ions at m/z 678 and 524 represent the $(M+H)^+$ species of the product peptides Tyr-Pro-Phe-Pro-Gly-Pro and Tyr-Pro-Phe-Pro, respectively. This spectrum was taken after 17 minutes of reaction within the mass spectrometer. Perhaps the most important aspect of this work is that it allows one to directly follow in a real-time analysis the release of reaction products during enzyme digestion of a substrate and to rapidly obtain structural information even with very small sample sizes. In this regard, the method provides an extremely sensitive, rapid, and mass specific detection system.

Enzyme Kinetics

In the determination of steady state reaction kinetic constants of enzyme-substrate reactions, FABMS also provides some very unique capabilities. Since these studies are best performed in the absence of glycerol in the reaction mixture, the preferred method is that which analyzes aliquots which are removed from a batch reaction at timed intervals. Quantitation of the reactants and products of interest is essential. When using internal standards, generally, the closer in mass the ion of interest is to that of the internal standard, the better is the quantitative accuracy. Using these techniques in the determination of kinetic constants of trypsin with several peptide substrates, it was found that these constants could be easily measured (8). FABMS was used to follow the decrease in the reactant substrate and/or the increase in the products with time and with varying concentrations of substrate. Rates of reactions were calculated from these data for each of the several substrate concentrations used and from the Lineweaver-Burk plot, the values of K_m and V_{max} are obtained. For example, Figure 3 shows the Lineweaver-Burk plot for the hydrolysis of the peptide Met-Arg-Phe-Ala by trypsin. The X-intercept is equal to $-1/K_m$, and the Y-intercept to $1/V_{max}$. From these data, the value of K_m was found to be 1.9 mM, V_{max} 0.31 μ moles/ml/min, and k_{cat} 7.1 sec^{-1} for this specific peptide.

The molecular specificity of FABMS opens new areas for kinetic analysis of enzyme-substrate interactions. Since the method is applicable to virtually all substrates whether or not they have a UV or visible spectrum, natural substrates can be used in place of synthetic substrates. Although much has been learned through use of the latter, their reaction constants can indeed be quite different than those of natural substrates.

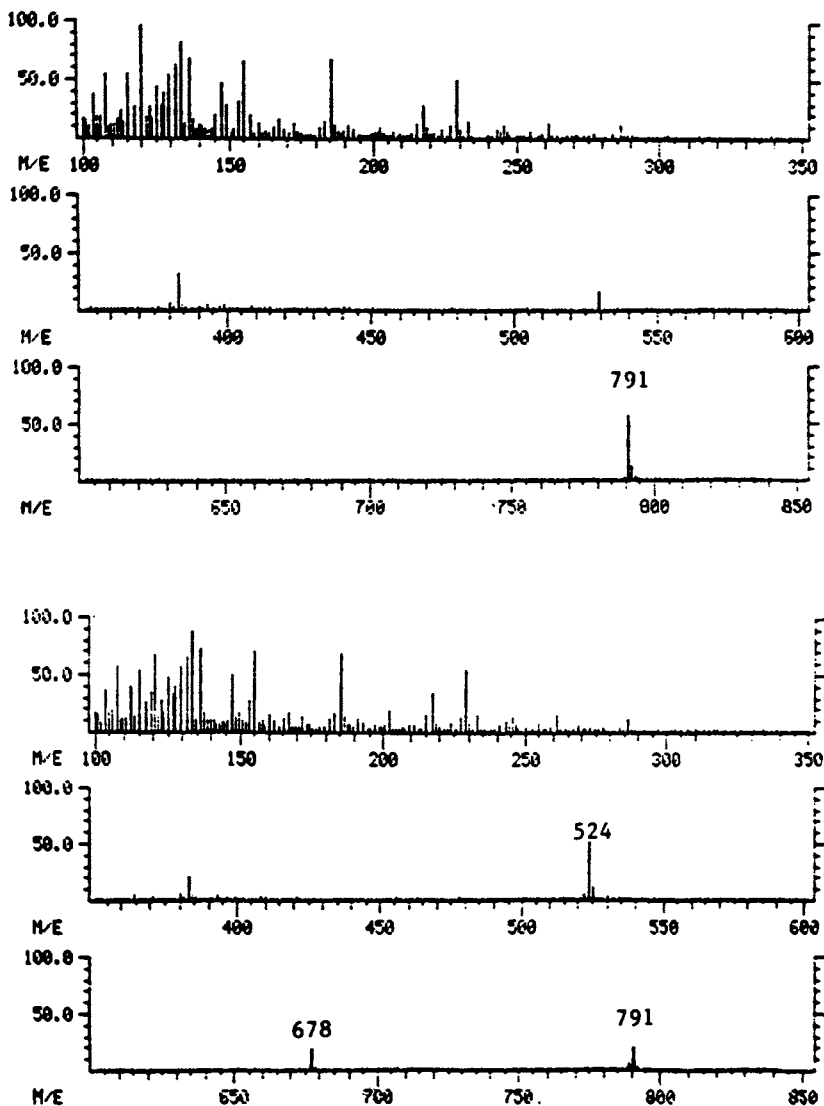


Figure 2. Hydrolysis of β -casomorphin, $(M+H)^+ = 791$, by proline specific endopeptidase in real-time within the mass spectrometer. Top: FAB spectrum before addition of enzyme. Bottom: FAB spectrum after 17 minutes of enzyme hydrolysis. Ions at m/z 678 and 524 correspond to new peptides produced in the reaction on the probe tip. Reproduced with permission from Ref. 3. Copyright 1983, L. A. Smith, Ph.D. Thesis, University of Texas Medical School.

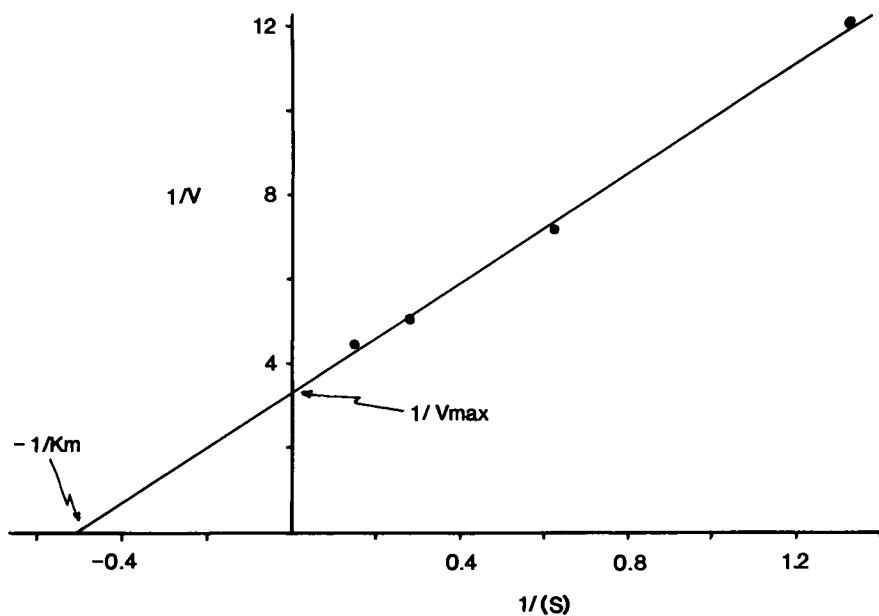


Figure 3. Lineweaver-Burk plot for the hydrolysis of Met-Arg-Phe-Ala by trypsin. The experimental parameters are described in reference 8. The velocity of the reaction, V , is expressed in units of $\mu\text{moles/ml/min.}$ and the substrate concentration, (S) in mM.

Conclusion

FABMS offers many advantages to the chemist in the analysis of reactions taking place in aqueous solutions as well as for the determination of ionic species under more static conditions. It brings to bear on those applications where reactions must proceed in aqueous solutions the molecular specificity of mass spectrometry. The extraction, concentration and derivatization steps formerly required for the analysis of organic compounds in aqueous solutions using other mass spectrometric ionization methods are often difficult and time consuming, but more importantly can lead to significant changes in the chemical dynamics which exist in the aqueous media.

One of the advantages of FAB over other soft ionization techniques is that it uses glycerol (or some other suitable liquid phase) which sets up a condition where the surface of the droplet is constantly replenished with sample molecules. A second advantage of the liquid matrix is that it allows solution chemistry to take place virtually at the site of analysis.

There is no doubt that FABMS has brought to the analytical chemist an important tool with which to probe molecular structure. It is a simple technique which can be employed on most mass spectrometers in use today. The near future promises utilization of the method in the investigation of important new concepts in biochemical and medical research.

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Applications of Fast Atom Bombardment in Bioorganic Chemistry

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The advent of FAB mass spectrometry has allowed the routine molecular weight determination of polar molecules, without derivatization, up to ca 3,000 Daltons, and in exceptional cases, within 1 mass unit to the region of 8,000 Daltons. This advance, coupled with FAB fragmentation, and enzymic digestion techniques, has allowed the rapid solution of a number of problems in protein and peptide chemistry - problems which were hitherto rather difficult to solve. Examples are given.

The discovery of FAB mass spectrometry in 1981 by Barber and co-workers¹ has, along with SIMS,² and Californium plasma desorption mass spectrometry,³ revolutionized the study of polar molecules by mass spectrometry. This paper is concerned with the application of FAB mass spectrometry to solve problems in peptide and protein chemistry.

The work to be presented has, when done in the author's laboratory, been carried out on a Kratos MS-50 mass spectrometer, fitted with a magnet possessing a mass range of 3000 Daltons at full accelerating voltage (8KV). Xenon atoms of 4-9 KeV translational energy have been used as bombarding particles into a matrix most commonly consisting of thioglycerol/diglycerol (1:1), or glycerol. The instrument is fitted with a post-acceleration detector, so that the translational energies of incoming ions can

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be increased by 9KeV, before impinging on an aluminized button. This device is indicated schematically in Fig. 1.

The most significant advantages of the FAB method are the ability to study underivatized peptides, a reduction in sample size, and the facility to study larger peptides. Peptides containing between 4 and 30 amino acid residues are conveniently studied with our present equipment.

A sample size of approximately 0.1 nanomoles is generally sufficient for molecular weight determination in either the positive or negative ion mode, but does not normally allow the sequence of amino acids to be determined. Larger sample sizes, typically between 1 and 5 nanomoles, afford some sequence information. Sequence ions are observed in the positive and negative ion modes from both N- and C-termini of the peptide and this may enable the complete sequence of the peptide to be determined.

The amount of sequence information available in the positive and negative ion FAB mass spectra of peptides varies considerably. The abundance of sequence ions is in part dependent on sample size but this is clearly not the only factor since large sample sizes (50 nanomoles) often fail to provide extensive sequence information for some peptides. Sequence information is frequently not complete and the absence of either C or N terminal sequence ions does not allow the complete sequence determination.

EI mass spectrometry of derivatized peptides complements FAB mass spectrometry but suffers from the disadvantage that larger sample sizes are usually required. For sample sizes less than 20 nanomoles and for high molecular weight peptides, alternative methods of generating sequence information are desirable. Carboxypeptidase digestion to generate a mixture of C-terminal fragments and chemical removal of N-terminal amino acid residues via the subtractive Edman degradation, coupled with FAB mass spectrometry offer a promising alternative.⁴

As an example where sequence information is available without the use of Edman or carboxypeptidase degradation, a study of calcineurin B may be cited. This work also allowed, most importantly, the determination of an N-terminal blocking group as myristic acid.

Calcineurin B is a calcium-binding protein first found in

bovine brain, and early work on this protein demonstrated that the NH_2 -terminus of calcineurin B was blocked. When calcineurin B was cleaved with cyanogen bromide, and applied to an HPLC column, a peptide (CB-1) lacking a free NH_2 -terminal amino acid was eluted as a sharp peak at 57% acetonitrile. The amino acid composition of CB-1 showed that it was a decapeptide containing only two hydrophobic amino acids. This indicated that the blocking group was much more hydrophobic than the acetyl, formyl or pyrrolidone carboxylic acid groups most commonly found at the N-termini of proteins.

Peptide CB-1 had M_r 1271 as determined by FAB mass spectrometry in the positive ion mode [$(M + \text{Na})^+ = 1294$, $(M + \text{H})^+ = 1272$] and in the negative ion mode [$(M - \text{H})^- = 1270$]. The number of carboxylic acid groups was determined from the positive ion FAB mass spectrum of the esterified peptide. An increase in M_r of 60 was observed, which corresponds to the formation of two methyl esters plus methanolysis of the C-terminal homoserine lactone. The M_r of the amino acid component of CB-1 was 1060, indicating that the M_r of the blocking group was 211.

When calcineurin B was digested with Staphylococcus aureus proteinase, a peptide, SP1, lacking a free NH_2 -terminal amino acid was also eluted from HPLC at 57% acetonitrile. Amino acid analysis showed it to be a tripeptide Gly,Asx,Glx. From the known specificity of S. aureus proteinase the C-terminal residue of SP1 must be Glu. FAB mass spectrometry established the M_r of SP1 as 528, and esterification of this peptide led to an increase in M_r to 556, which corresponds to the formation of two methyl esters. Since SP1 has two free carboxyl groups, the sequence of SP1 must be X-(Gly,Asn)-Glu and the M_r of the blocking group must be 211.

The assignments of sequence ions observed in the FAB mass spectrum of CB-1 and its methyl ester are given in Table I, and suggested that the sequence of CB-1 was:

Gly-Asn-Glu-Ala-Ser-Tyr-Pro-Leu-Glu-Hsl

Assuming that the blocking group X is linked to the NH_2 -terminal glycine by the usual amide bond, then hydrolysis should yield a carboxylic acid $M_r = 228$. This corresponds to the M_r of a C_{14} saturated fatty acid. The mass spectra are consistent with the supposition that X is $\text{C}_{13}\text{H}_{27}\text{CO}-$. This possibility was confirmed by

Table I A
Assignment of the sequence ions in the
FAB mass spectra of decapeptide

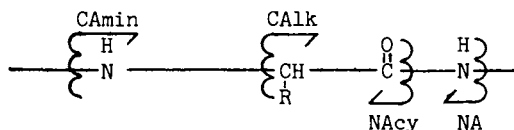
Type of fragment ion ^a	M _r -Values of fragment ions											M _r determining peak	
	X	Gly	Asn	Glu	Ala	Ser	Tyr	Pro	Leu	Glu	Hsl		
+ Na						621	708			968	1081	1210	1294
+ NAcy								856	953	1066			1294
+ CAmin	1027		913	784	713								1294
+ CAmin	1005		891	762									1272
+ CALk			897	768									1294
- NA						597	684			944	1057	1186	1270
- NAcy						582		832	929	1042	1171		1270
- CAmin	1003		889	760	689								1270
- CALk	988		874	744									1270

Most of the sequence ions observed in the positive ion (+) mode are cationised by NA⁺. The base peaks in the positive ion FAB mass spectra of peptides that lack basic functional groups as in CB-1 often correspond to the M_r of peptides cationised by the formation of adducts with Na⁺ and/or K⁺, traces of which are usually present in the matrix.

Table I B
Assignment of the sequence ions in the
FAB mass spectra of the decapeptide ester

Type of fragment ion ^a	M _r -Values of the fragment ions										M _r determining peak		
	X	Gly	Asn	Glu- -OMe	Ala,Ser	Pro	Leu	Glu- -OMe	Homo- -Ser- -OMe				
+ Na													
+ NAcy													
+ CAmin	1087		973										1354
+ CALk			957	814									1354

^aFragment ions are named as follows:



Bond cleavages are accompanied by a hydrogen transfer to the charged fragment except in the NAcy case. Positive and negative signs indicate cationic and anionic fragment ions, respectively.

^bDue to cyclic nature of the proline residue fragmentation of NA type does not produce fragment ions.

isolating the blocking group as its methyl ester. On gas chromatography, this ester co-migrated with methyl myristate.

We were also able to use FAB mass spectrometry to determine the amino acid sequence around the active site serine in the acyl transference domain of rabbit mammary fatty acid synthase.⁶ The synthase was labelled in the acyl transferase domain(s) by the formation of O-ester intermediates after incubation with [¹⁴C]-acetyl- or malonyl-CoA (Fig. 2A). The modified protein was then digested with elastase (Fig. 2B), and radioactive material isolated via successive purification steps on Sephadex G-50 and reverse phase HPLC. The isolated peptides were then sequenced by FAB MS. The data summarized in Table II established the sequences of both the acetyl and malonyl hexapeptides to be N-acyl-Ser-leu-Gly-Glu-Val-Ala.

The N-terminal location of the acyl group was confirmed by showing that the molecular ions were identical after treatment with acetic anhydride, which would acetylate a free amino group. Since the linkages between the acetyl and malonyl groups and intact fatty acid synthase are sensitive to hydroxylamine (1 M, pH 9.5, 2.0h, 38°C; unpublished work), the initial acylation cannot be at an amino group. An O→N migration must have occurred after proteolytic digestion.

Our own work is now evolving, in part, to use FAB mass spectrometry to determine which portions of some genes are expressed in the frog Xenopus laevis. The genes in question are those coding for some of the peptides which are secreted through the frog skin when the frog is stimulated (by handling, or by infection with epinephrine or nor-epinephrine). These peptides are significant because of the remarkable structural, and physiological activity, similarities which exist between them and a number of mammalian neuropeptides. If known (and sequenced) frog skin peptides are used as a guide to synthesize appropriate c-DNA probes, the genes which code for these peptides can be isolated and sequenced. However, it is then a problem to know which other parts of the gene are expressed in peptide production. FAB mass spectrometry has proved to be a very powerful tool in solving this problem. FAB MS has been used to show that a large number of hitherto unidentified peptides are excreted by Xenopus laevis, although for most of these only MH⁺ ions

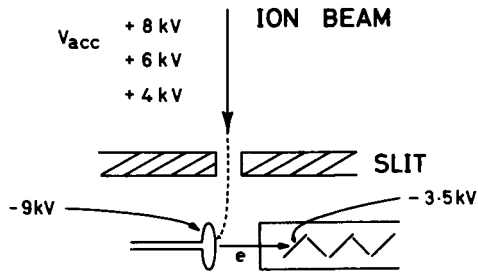


Figure 1. Schematic illustration of the post-acceleration detector.

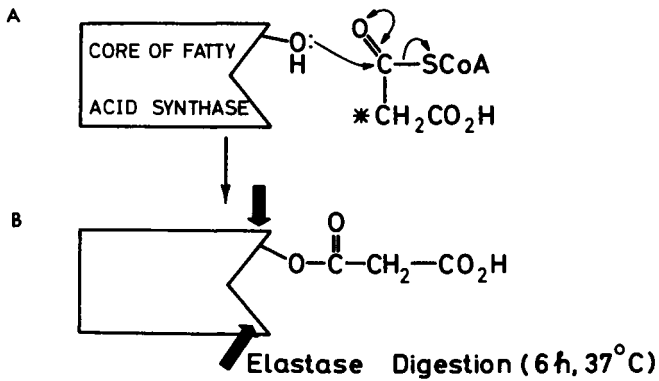
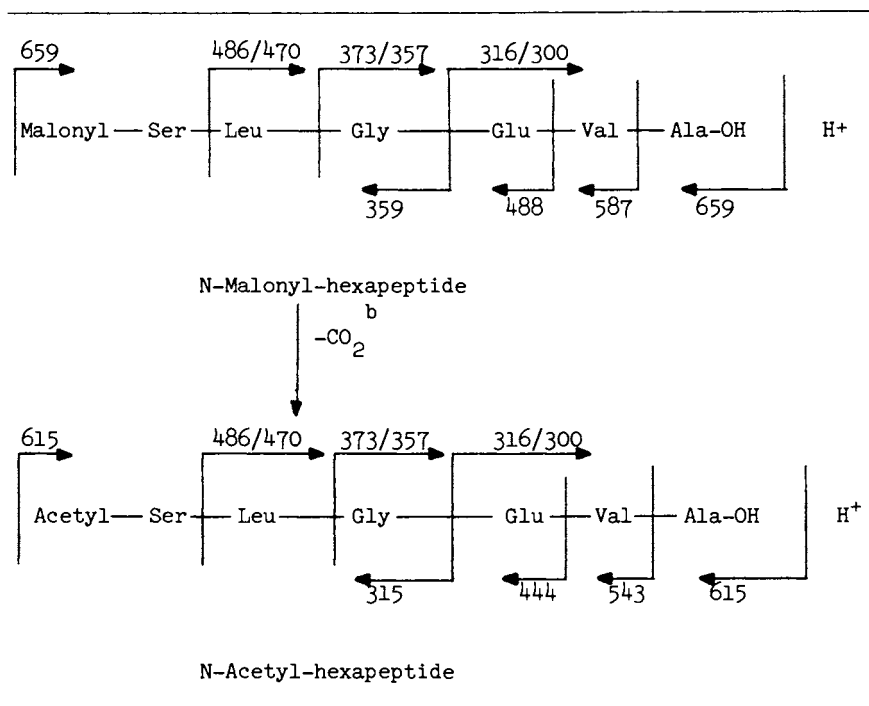


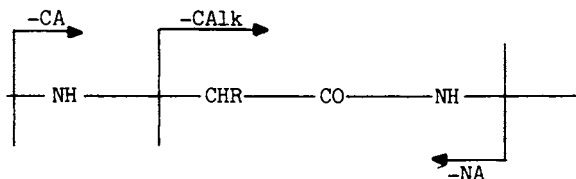
Figure 2. Schematic illustration of protein radio-labelling and elastase digestion.

Table II

Amino acid sequence information^a derived from negative ion FAB mass spectra of the malonyl- and acetyl-hexapeptides^b



^aSequence ions observed in the negative ion FAB mass spectra of the above peptides are as follows:



where the -CA and -NA cleavages occur with hydrogen transfer to the charged fragment.

^bSome decarboxylation of the malonyl group to produce an acetyl group was observed in the FAB mass spectra of the N-malonyl-hexapeptide.

are observed in peptide mixtures. However, when these molecular ions are considered in the light of known gene sequences, and in the light of possible processing sites in the peptides which they would produce if transcribed and translated, full peptide sequences corresponding to the molecular ions can be proposed. These peptide sequences can then be validated (or otherwise) by one or two cycles of Edman degradation, with re-determination of the molecular weight by FAB (as outlined previously in this article) after each cycle.⁷ Although the above work is not completed, the principle by which FAB mass spectrometry can be used in conjunction with known gene sequences, and in particular to check their accuracy, can be illustrated by reference to the recent work of Gibson and Biemann.⁸

It is obvious that it is prudent to check the correctness of the amino acid sequence derived from the base sequence of the gene not only at the NH_2 and COOH termini, which is the common practice, but throughout the entire protein. This would help to uncover any significant errors as well as address the possibility of post-translational modifications.

For checking the correctness of a proposed structure the protein is hydrolyzed at specific sites - i.e., with trypsin - to produce a pool of smaller peptides, which is then partially separated by HPLC into five or six fractions. Each fraction is then subjected to FAB-MS, which allows the determination of the molecular weights of most or all of the peptides present in each fraction. These values are then compared with the molecular weights of the tryptic peptides predicted from the DNA deduced amino acid sequence. The fractions can then also be subjected to Edman degradation(s) and the molecular weights of the shortened peptides determined by FAB-MS to identify the NH_2 -terminal amino acid(s) of each peptide from the change in its molecular weight. For example, a tryptic digest of the protein Gln-tRNA synthetase was separated into six crude fractions by HPLC to remove the enzyme, reagents, salts, and other contaminants and also to reduce the complexity of the original digest, which, in turn, reduces the complexity of the resulting FAB mass spectra. There were two predicted tryptic peptides of M_r s 736 and 1379, respectively, which is 10 daltons less than two unmatched experimentally found peptides (M_r s 746 and 1389). The former cover the

amino acid positions 7-12 and 1-12, i.e., they are overlapping peptides from the NH₂ terminus of Gln-tRNA synthetase. Only the pair serine/proline differs by 10 daltons. The preliminary sequence indeed contained serine in position 7, which is common to both, and the codon used for serine was TCG, which could be converted to proline codon CCG if base 19 were C rather than T.

Re-inspection of the DNA sequence analysis data revealed that not only base 19 is C but also base 18. Because both CGT and CGC code for arginine, the corrected sequence now contains an arginine-proline bond, which trypsin splits very slowly. This is probably the reason why both tryptic peptides (positions 1-12 and 7-12) were observed. The following are the preliminary and final DNA and amino acid sequences of this region.⁸

AGT-GAG-GCA-GAA-GCC-CGT-TCG-ACT-AAC-TTT-ATC-CGT
Ser-Glu-Ala-Glu-Ala-Arg-Ser-Thr-Asn-Phe-Ile-Arg
AGT-GAG-GCA-GAA-GCC-CGC-CCG-ACT-AAC-TTT-ATC-CGT
Ser-Glu-Ala-Glu-Ala-Arg-Pro-Thr-Asn-Phe-Ile-Arg

Conclusion

It is evident from the foregoing examples that FAB mass spectrometry is a powerful technique in several aspects of protein and peptide chemistry. This is particularly true in determining the nature of blocking groups in proteins, in checking the sequences of bases in genes (by examining the resulting protein), and in determining which portions of genes are expressed (when the peptide products are readily available as relatively pure components, or simple mixtures).

Acknowledgments

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Use of Secondary Ion Mass Spectrometry to Study Surface Chemistry of Adhesive Bonding Materials

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Secondary Ion Mass Spectrometry used as a solo instrument or in concert with other methods has proven to be an excellent technique for studying the surface chemistry of adhesive bonding materials. The application of SIMS is shown in relation to pretreatments of metals and alloys, chemistry and structure of adhesives, and locus of failure of debonded specimens.

The idea of building structures which are stronger and more durable while at the same time lighter in weight would appear contradictory, but has been accomplished using adhesive bonding and composite materials. Such novel construction and materials are used extensively in the aerospace and automotive industries. Since these structures depend on the interaction of surfaces and the formation of interfaces, it is necessary to develop methods of physical and chemical characterization which are applicable to such types of materials. Secondary ion mass spectrometry, used either as a stand alone instrument, or as a complement to other techniques, has proven of value for characterization of original materials and failure surfaces following use or accelerated test. Since these proceedings contain detailed descriptions of the SIMS technique and its variations, emphasis will be placed in this account on application of the method to surface preparation and adhesive bonding. Theoretical and practical operational aspects of SIMS will be considered only insofar as they pertain to adhesive bonding research.

Discussion

In deciding which surface chemistry tools to use for the broad area of adhesion and for adhesive bonding in particular, a number of aspects must be considered. More often than not, a combination of instruments must be used to take advantage of the unique information provided by each method. Table 1 shows some of the important aspects of adhesive bonding and some of the characterization methods which are applicable in these areas¹. The acronyms are those used in the review by Powell².

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It is seen in Table I that SIMS is applicable to several areas of investigation in adhesive bonding. SIMS may be used in a variety of ways including species imaging of the surface (SIIMS) which may be especially useful for clarifying mixed mode failure surfaces. The main features of SIMS are shown in Table II³.

Chemistry of Adherends

A determination of the chemistry of metallic adherends presents problems of each of the areas discussed here. Many of the surface chemical techniques are applicable to the analysis of adherends, and because of the stability and good conductivity, decomposition and surface charging are not problems. Surface chemical analysis is usually devoted to (1) determining the amount and distribution of elements purposely placed on the surface to impart a desirable property, and (2) detection and monitoring of impurity elements which may be deleterious to the adhesive bond. Many chemical etching and oxidizing treatments are used on metal and alloys to enhance adhesive bonding of the surface. Enhancement comes about by roughening of the surface and by changing the surface chemistry. In addition, some thermal treatments, such as the bond cure in adhesive bonding, may affect the composition of the surface, either by introducing impurities or by increasing or decreasing a concentration of alloying elements at the surface. McDevitt and co-workers^{4, 5, 6} used SIMS and other modern surface analysis tools to analyze several aluminum alloys following chemical treatment for adhesive bonding. They found a number of interesting phenomena, including the formation of an interfacial region rich in copper on the structural alloy 2024 aluminum. The concentration and width of this potential weak boundary layer was found to vary depending on the etching conditions of the sulfuric acid-sodium dichromate solution. This solution is related to the surface preparation method known as the FPL etch. Similar results were obtained more recently by Sun and Co-workers⁷. The formation of such potential weak boundary layers may influence both the initial bondability and the long time durability of the adhesive bond. Baun et al used Ion Scattering Spectrometry (ISS), Secondary Ion Mass Spectrometry (SIMS) and Auger Electron Spectrometry (AES) to analyze a variety of metal and alloy adherends. These authors also used several surface treatments on titanium and titanium alloys and analyzed them by surface techniques such as ISS, SIMS, AES and SEM^{9, 10, 11}. Large differences in chemistry were observed on titanium and its alloys depending on the surface treatments. Some possible steps in the surface preparation of titanium alloys for adhesive bonding are shown in Table III¹².

Table I
Aspects₁ of adhesive bonding and applicable surface characterization methods

Adherend chemistry	
AEAPS, AEM, AES, APS, BIS, CIS, CL, EM, ES, EXAFS, IIRS, IIXS, IMMA, IS, ISS, LMP, PES, RBS, SIMS, SXAPS, SXES	
Adherend structure and morphology	
AEM, ELL, EM, HEED, IMMA, LEED, SEM, SIIMS, SRS, STEM, TEM, XEM, XRD	
Adhesive chemistry	
AES, AIM, ASW, ATR, ESR, HA, IRS, ISS, LS, PES, SIMS, UPS, XPS	
Adhesive structure and morphology	
ATR, IR, UV, RAMAN, SEM	
Interaction of polymers with metals	
AES, AIM, ASW, CPD, ELL, EELS, ESDI, ESDN, FD, FDS, HA, IRS, IR, ISS, ISD, LEED, LS, PD, SC, SIMS, UPS, XPS, RAMAN	
Failure surfaces (locus of failure)	
AES, ATR, ELL, ISS, SIMS, PES, XPS, SEM, SXES, SXAPS, SRS, UPS	

Table II
Main features of SIMS as a surface analysis method

Positive	- Information depth in the "monolayer range"
	- Detection of all elements including hydrogen
	- Detection of chemical compounds
	- Isotope separation
	- Extremely high sensitivity for many elements and compounds ($\sim 10^{-6}$ monolayers)
	- Quantitative analysis after calibration
	- Negligible destruction of the surface (Static SIMS)
	- Elemental profiling (Dynamic SIMS)
	- Elemental and Cluster Imaging
Negative	- Large differences in sensitivity for different "surface structures" (factor 1000)
	- Problems in quantitative interpretation of molecular spectra
	- Ion induced surface reactions
	- Surface Charging in Insulators

Table III
Surface Preparations of Titanium Alloys for Adhesive Bonding¹²

1 Clean	2 Etch	3 Convert	4 Modify
<u>Solvent</u>	<u>Acids</u>	<u>Chemical</u>	<u>Boiling H₂O</u>
1. Liquid	HF, HNO ₃ ,	<u>Phosphates</u> ,	<u>Boiling H₂O + ?</u>
2. Vapor	H ₂ SO ₄ ,	<u>Fluorides</u> ,	<u>Dry Heat</u>
<u>Abrasion</u>	H ₃ PO ₄	etc.	<u>Heat + Humidity</u>
<u>Alkaline</u>	<u>Combinations</u>	<u>Anodization</u>	<u>Absorption</u>
<u>Combinations</u>	<u>Alkaline</u>	dense	<u>UV, Ions</u> ,
	<u>Abrasive</u>	porous	
	<u>Slurry</u>	<u>Combinations</u>	<u>Corona, etc.</u>

The surface chemistry of Titanium alloys varies with each physical or chemical treatment. An example of ISS/SIMS results from a typical chemical pretreatment for Ti-6Al-4V is seen in Figure 1. Here the sample was degreased, etched in HNO₃/HF and converted with a mixture of HF, NaF and Na₃PO₄ in aqueous solution. Spectra from this surface shows that it is far from being a simple oxide. An ISS spectrum from a typical TiO₂ surface is shown in the inset for comparison. Note in the SIMS data the appearance of the molecular ion TiF⁺, which suggests the combination of fluorine and titanium. It is also interesting that sodium and fluorine do not seem to be associated even though appreciable amounts of each occur on the surface. SIMS data in Figure 2A for a typical anodized oxide formed in a neutral Na₂HPO₄ + H₃PO₄ solution at 50 volts shows a spectrum similar to the crystalline oxide, rutile. These thin anodized specimens show large amounts of TiO⁺ in relation to Ti⁺. It is interesting that the alloying element vanadium is nearly absent in the oxide layer. The surface chemistry of porous anodized oxides are much different as seen in Figure 2B where the SIMS spectrum is shown for a thick oxide formed in the same electrolyte as A, but at 100V which is near the breakdown voltage¹³ for this electrolyte and titanium. SIMS data show hydrocarbons, alkali elements, calcium, and most importantly evidence of phosphorus (probably phosphate ion) in the porous film. AES elemental profiles show that phosphorus concentrations are high at the surface and continue on into the film.

Initial bondability of anodized surfaces was tested in the lap shear configuration using numerous commercial epoxy adhesives. With one exception, all surfaces proved to be bondable and gave acceptable lap shear values. That exception was an anodized film formed

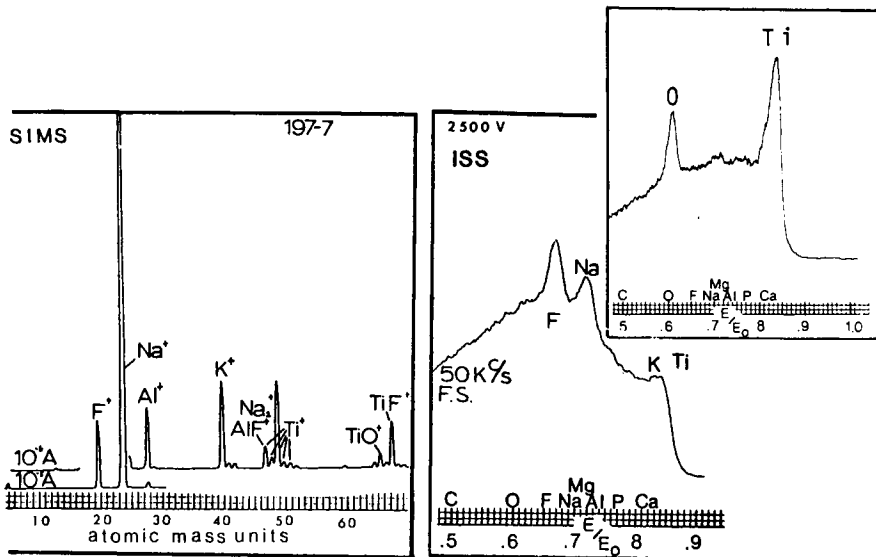


Figure 1. ISS/SIMS Data for Ti-6Al-4V Alloy Etched with HF/HNO_3 and Converted with $\text{HF}/\text{NaF}/\text{Na}_3\text{PO}_4$. Inset shows typical ISS Spectrum from TiO_2 .

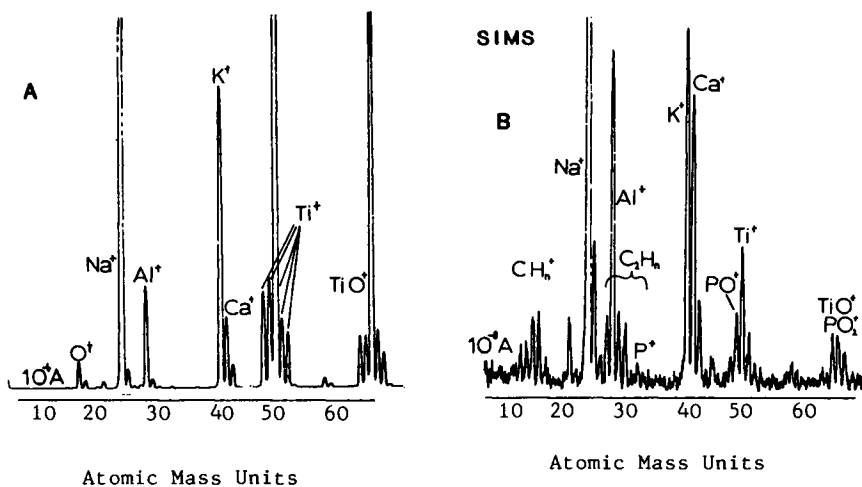


Figure 2. SIMS Data for Ti-6Al-4V Alloy.
 A. Specimen Anodized in $\text{Na}_2\text{HPO}_4 + \text{H}_3\text{PO}_4$ (pH = 7) at 50 Volts.
 B. Specimen Anodized in $\text{Na}_2\text{HPO}_4 + \text{H}_3\text{PO}_4$ (pH = 7) at 100 Volts (Breakdown)

in any electrolyte containing fluorine ions. The result was rather unexpected since a commercial patent calls for the addition of fluorine ions to a solution to increase the current density and subsequently the porosity of the anodized film for adhesive bonding. The adhesive showed good adhesion to the oxide film in these cases. Failure often occurred interfacially at the oxide/metal interface even using lap shear specimens. When a test in which pure shear was placed at the interface, as in the three-point-bend method, then failure always took place interfacially at the oxide/metal interface. Peel tests on anodized films in which fluorine was present also showed interfacial failure in most tests. Peel strength in the anodized regions was virtually zero. SIMS spectra showed fluorine to be present on these surfaces (both on the adhesive and adherend).

An interesting result was the appearance of F^+ in the residual gas analysis when the electron beam in AES was placed on the sample, suggesting easy desorption and a very unstable surface. In fact, when electron beam currents were not minimized, the fluorine frequently was desorbed completely, and did not appear in the Auger spectrum.

SIMS spectra from simple etching processes also showed interesting results. Figure 3 shows the high activity of etched surfaces, and tendency to react with elements found in tap water. Note that the calcium from the water appears to combine with fluorine left on the surface by the hydrofluosilicic acid, but there is little suggestion of any reaction between fluorine and titanium to form a compound. Also of interest is the very low concentration of the alloying element aluminum on these surfaces in view of the high secondary ion yield from aluminum. Vanadium, which was not observed in the anodized specimens, appears prominently on most acid etched surfaces. Aluminum alloys show equally interesting surface chemistry changes with processing. Many aluminum alloys following processing including hot rolling and heat treatment, show surface elemental concentrations far different from true bulk composition. Even following cleaning such as degreasing and alkaline bath, appreciable differences are seen between surface and bulk as shown in Figure 4. Here SIMS and ISS spectra are shown for a degreased and lightly alkaline cleaned 2024 alloy. SIMS shows a large amount of Mg on the surface and the ISS ratio of O to Mg-Al is about that of MgO. One advantage of SIMS showing its complementary nature is seen here where Mg and Al cannot be resolved in ISS but is easily separated in the SIMS spectrum. When the surface is etched in a stronger alkaline solution, the SIMS spectrum (B) shows a much smaller ratio of Mg to Al, much more in line with the magnesium content of approximately 1.5%.

Other surface treatments which etch away the surface still leave the surface composition much different from the bulk. Figure 5 shows the ISS/SIMS spectra for 2024 aluminum alloy etched in a mixture of nitric and hydrofluoric acids. As is seen in both spectra, copper is prominent on the surface. This is a very mild case of surface smutting⁸. Surface smut is observed in many materials which are heavily etched in acid or alkaline media. Smut on stainless steel has been studied by ISS/SIMS¹⁴. An example of such spectra on a smutted 304 stainless steel surface is seen in Figure 6

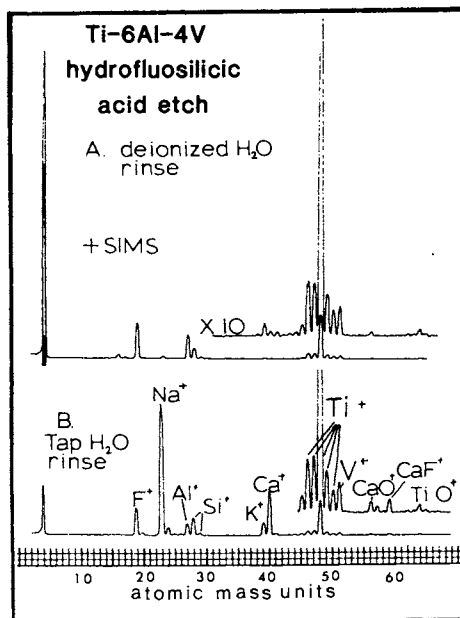


Figure 3. SIMS Data from Ti-6Al-4V Alloy.
 A. Etched in Hydrofluosillicic Acid, Deionized H₂O Rinse
 B. Etched in Hydrofluosillicic Acid, Tap H₂O Rinse

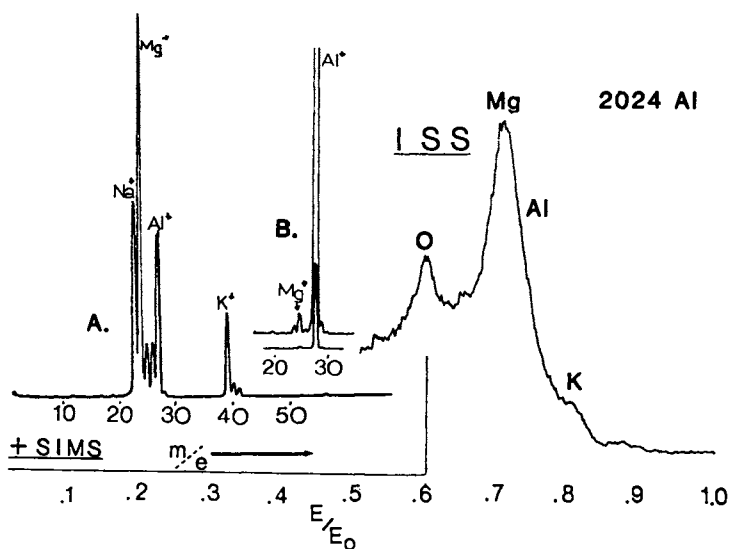


Figure 4. ISS/SIMS Data From 2024 Aluminum Alloy, Degreased and Gentle Alkaline Clean. Inset shows SIMS Spectrum from Bulk Alloy.

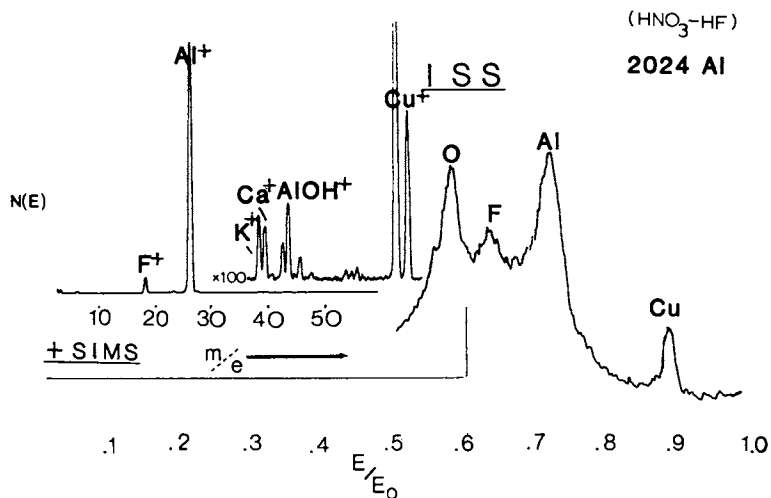


Figure 5. ISS/SIMS Data From 2024 Aluminum Alloy, Etch in HF/HNO₃.

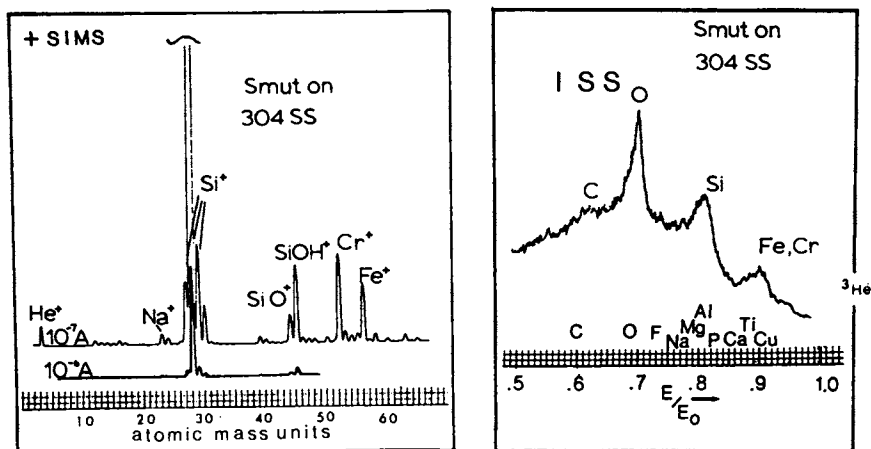


Figure 6. ISS/SIMS Data From Smutted Stainless Steel

and is found to be mostly silicon and oxygen. Even when the surface is visibly desmuted, often traces remain which are measurable by ISS/SIMS. Smutted and de-smutted surfaces were examined by several analytical techniques. The results of which are summarized in Table IV.

Table IV
Species found on 304 stainless steel by surface analysis techniques

Technique	Smutted in H_2SO_4	De-smutted in $H_2SO_4-CrO_4$
AES	Si, O, Cl, C, Cu, Fe, Cr, Ni	O, C, S, Fe, Cr, Ni
ISS	Si, O, C, Cu, Fe, Cr	O, Na, Fe, Cr
+SIMS	Si^+ , Na^+ , SiO^+ , $SiOH^+$, Cu^+ , CH_n^+ , Fe^+ , Cr^+ , Ni^+ , Cu^+	Na^+ , K^+ , Si^+ , S^+ , OH^+ , CH_n^+ , Fe^+ , Cr^+ , Ni^+
-SIMS	$C_nH_n^-$, O^- , OH^- , SiO^- , SiO_2^- , SiO_3^- , SiF^- , $SiOF^-$, SiO_2F^- , FeO_2^-	$C_nH_n^-$, O^- , OH^- , Cl^- , SiO^- (greatly reduced) CrO^- , CrO_2^- , CrO_3^- , FeO_2^-
XPS	C^a , O, S, Si^b , N, Cu, Fe, Cr, Ni	C, O, Fe, Cr, Ni

^a More than one form.

^b Oxide form.

Chemistry and Structure of Adhesives

SIMS is very sensitive to surface molecular structure, showing fragmentation pattern changes even on the same material but given different treatment. Figure 7 shows SIMS data for a commercial two-part epoxy mixed under the same conditions and then divided into two portions, one cured 24 hours at room temperature and the other cured one hour at 250°F.

As can be seen, some larger fragments are seen in the sample held at elevated temperature, and sodium has segregated to the surface. Such segregation is very common in high temperature cured specimens, where sodium is often found at the failure surface in an adhesive failure mode. ISS/SIMS data from the adhesive side of a titanium-epoxy failure interface from a tensile test specimen are shown in Figure 8.

The fragmentation pattern is different (compared to the two part epoxy) from this temperature sensitive tape epoxy and sodium is seen at the failure interface. Sodium was also observed on the matching titanium side of the specimen.

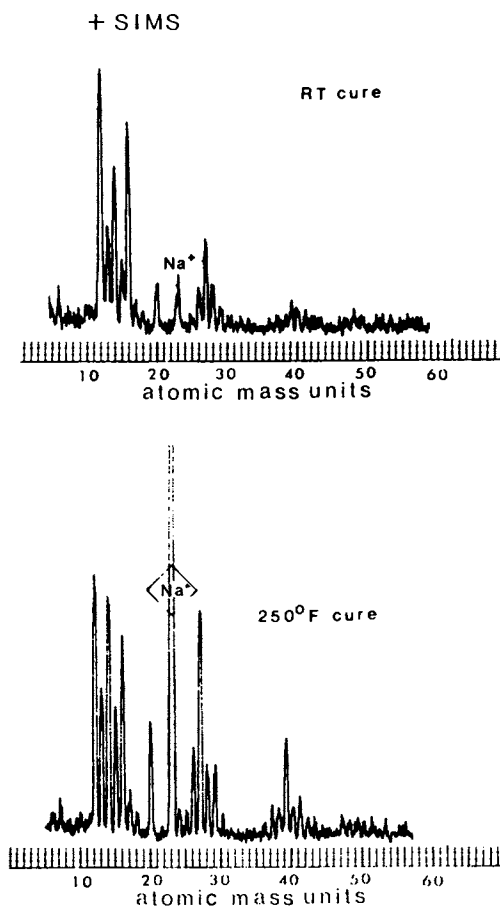


Figure 7. SIMS Data From Two Part Epoxy Cured at Room Temperature for 24 Hours and at 250°F for One Hour.

Failure Surfaces

SIMS and the other complementary surface spectroscopies are extremely useful in determining just where an adhesive bonded structure actually separated. Following failure during service or test, it is not always obvious just where the failure took place. Often a failure is termed "adhesive" or interfacial just because the adherend appears to be "clean" (no adhesive). In actuality the failure may have occurred in a weak boundary layer very near an interface. A failure may also be initiated in one area and progress into another weaker area. Figure 9 shows a model of an adhesive bond and some of the features contributing to a fingerprint spectrum which pinpoints the exact locus of failure. Examples of these chemical "fingerprints" were shown earlier in ISS/SIMS spectra from alloy surfaces in which alloying and impurity element distributions were far different from bulk values. In addition, some of the interfacial regions show very characteristic spectra depending on past history or purposely added elements. For example, as mentioned earlier, bonds on metals or alloys which have been heated following etching or during processing often show weak boundary layer failures in which large quantities of alkali elements have migrated to the interface. Such a failure surface along with the original Ti-6Al-4V etched surface shown in Figure 10 originated with research on modeling of gold adhesion to titanium alloys. Following easy peel of the gold, the surface was found to produce a high sodium signal in the SIMS spectra which had not been observed in the original surface. The gold side of the failure also contained a large amount of sodium.

Purposely added elements also often help to pinpoint an exact locus of failure as illustrated in Figure 11. Here a failure is shown to have occurred near the primer-aluminum alloy interface as indicated by SIMS and other spectra which showed elements of the corrosion inhibitor (strontium chromate) on the failure surfaces. Similar work using SIMS has been used to infer environmental corrosion resistance¹⁵ and to determine thickness of thin silanized surfaces¹⁶

SUMMARY

Ion beams provide useful information either as a diagnostic tool or as a precision etching method in adhesive bonding research. The combination of SIMS with complementary methods such as ISS or AES provides a powerful tool for elemental and limited structural characterization of metals, alloys and adhesives. The results shown here indicate that surface chemistry (and interface chemistry) can be decidedly different from bulk chemistry. Often it is this chemistry which governs the quality and durability of an adhesive bond. These same surface techniques also allow an analysis of the locus of failure of bonded materials which fail in service or test.

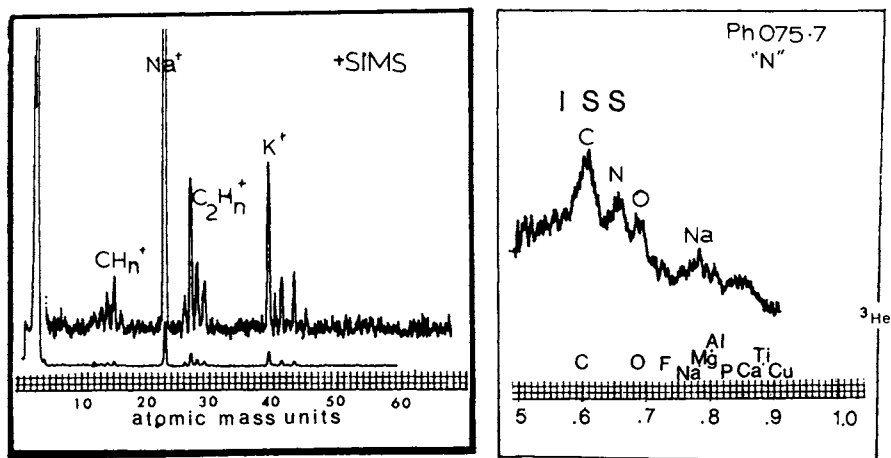


Figure 8. ISS/SIMS Data From Tape Epoxy Adhesive Debonded From Titanium

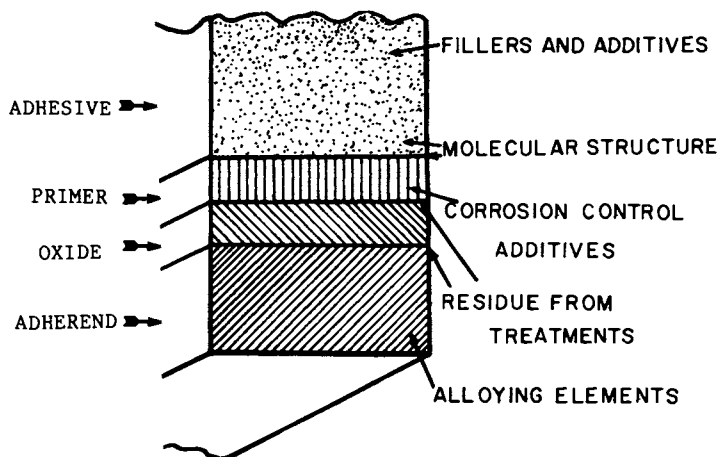


Figure 9. Model of Adhesive Bond Showing Impurities and Additives

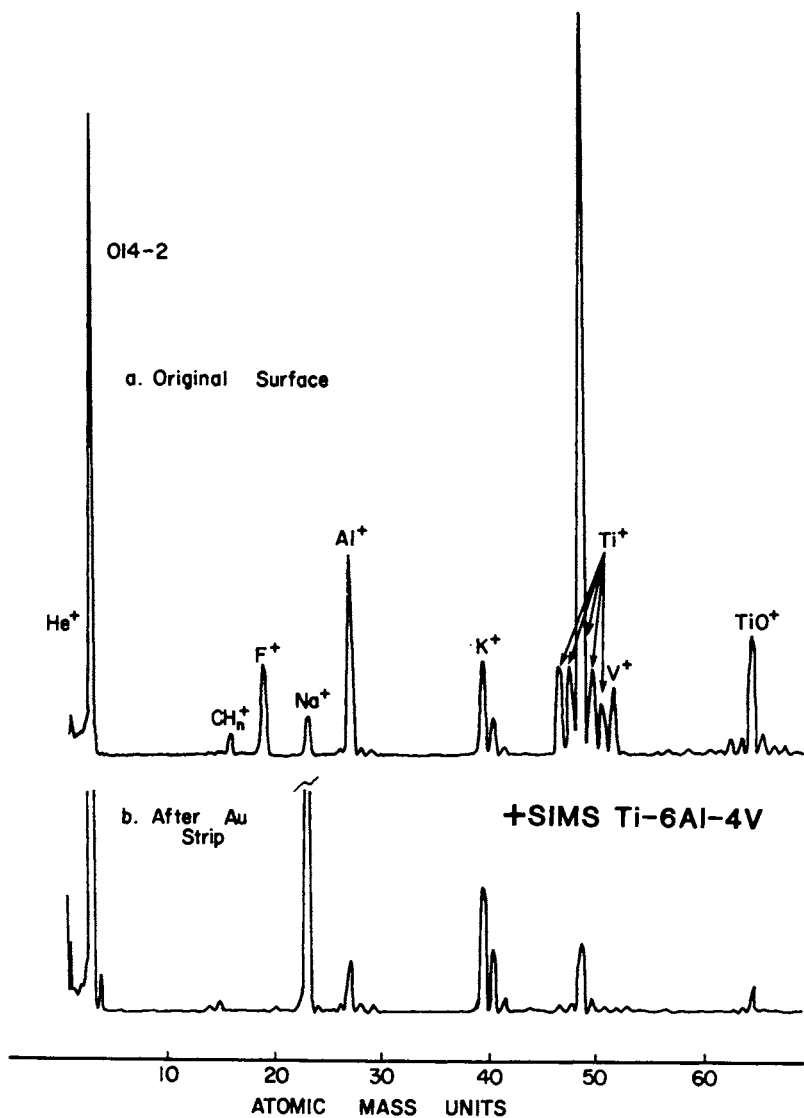


Figure 10. SIMS Data from Ti-6Al-4V Alloy.
A. Original Surface of Titanium Alloy
B. Surface After Gold Stripped From Titanium Alloy

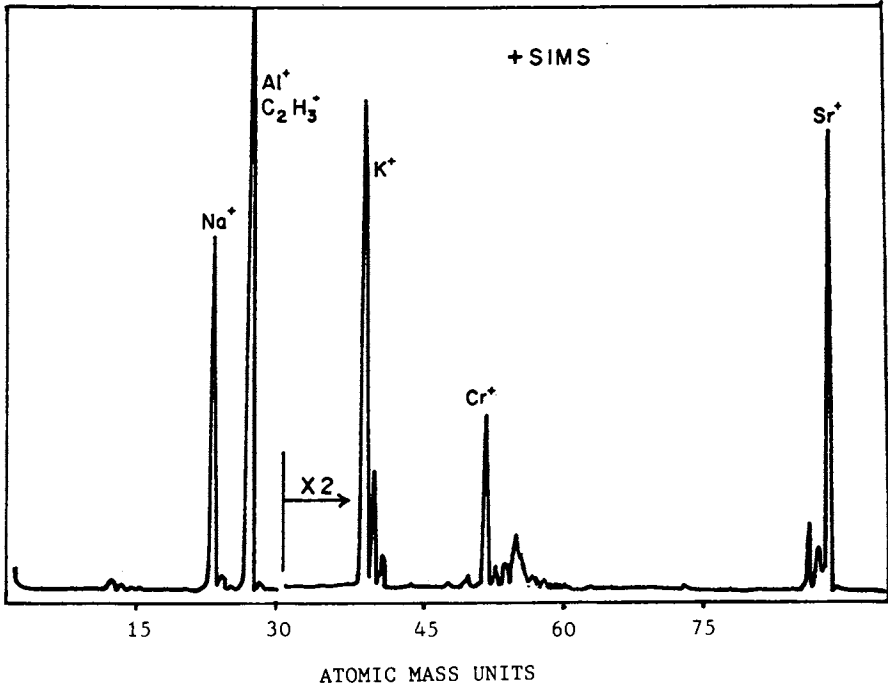


Figure 11. SIMS Data From Aluminum Alloy Failure Surface Containing Corrosion Control Additive (Strontium Chromate)

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